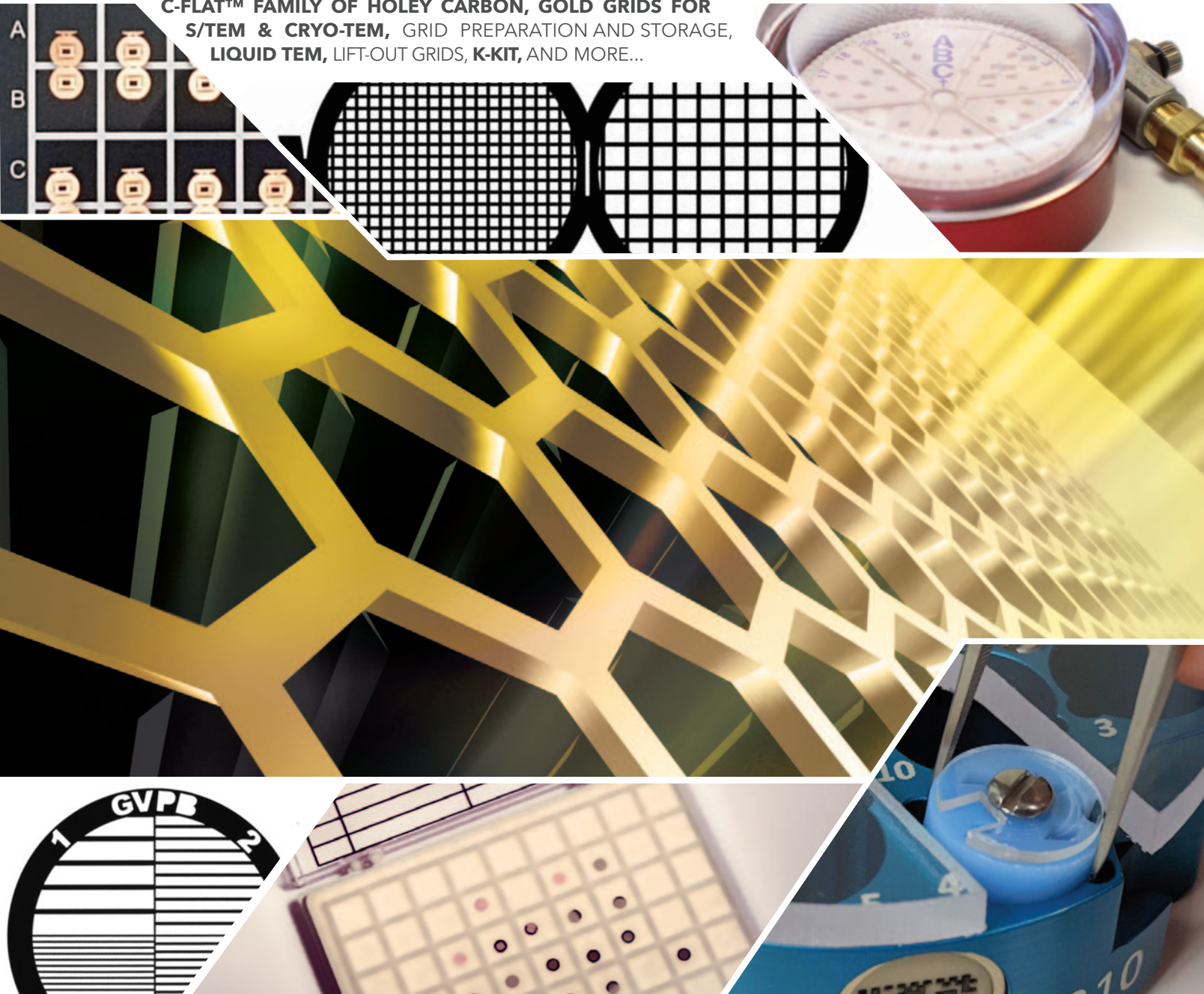


EMS GRIDS & TEM SUPPORT FILMS CATALOG

SPECIMEN SUPPORT GRIDS, **SUPPORT FILM ON GRIDS**,
QUANTIFOIL® HOLEY CARBON FILMS, **TEM WINDOW GRIDS**,
GRAPHENE AND GRAPHENE OXIDE SUPPORT FILMS FOR TEM,
C-FLAT™ FAMILY OF HOLEY CARBON, GOLD GRIDS FOR
S/TEM & CRYO-TEM, GRID PREPARATION AND STORAGE,
LIQUID TEM, LIFT-OUT GRIDS, **K-KIT**, AND MORE...



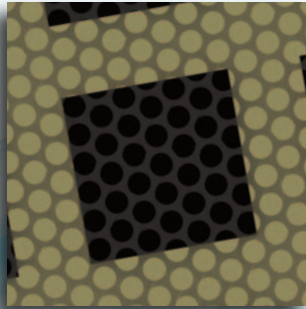
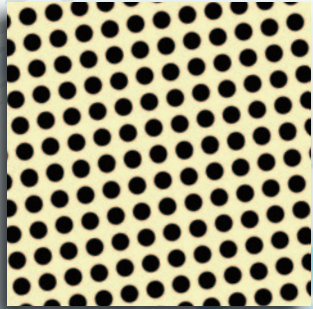
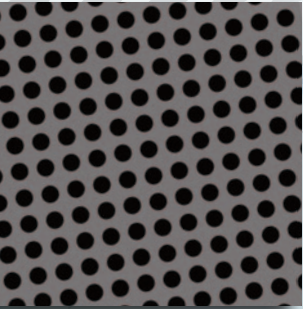
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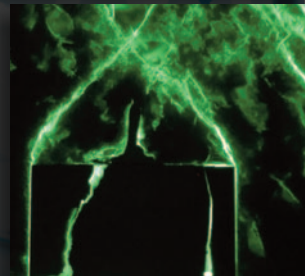
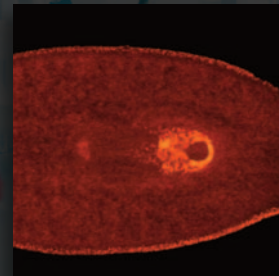
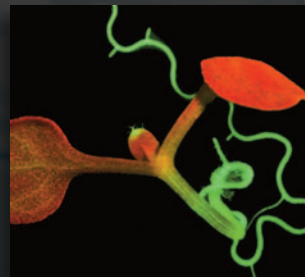
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EMS GRIDS & TEM SUPPORT FILMS CATALOG

EDITION IV

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NEW PRODUCTS...

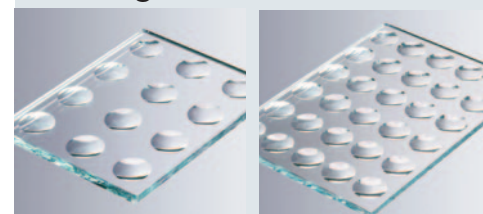
NEW Gilder Parallel Bars, Type GVPB

This new grid provides four levels of parallel bar specimen support. Quadrants are separated by crenelated bars.



See page 5.

Marienfeld Superior™ Staining Plates



Made of float glass, with beveled edges and polished cavities.

See page 84.

NEW Carb-N-Grids™ 2 & 4 Post 3mm Lift-Out Grids



Durable carbon lift-out grids that facilitate precise Elemental Analysis.

See page 19.

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SPECIMEN SUPPORT GRIDS

TECHNICAL TIP

Shiny Side or Rough Side?

Retention of sections on grids during poststaining and immunocytochemical procedures frequently is of crucial importance in the electron microscopy laboratory. Opinions differ regarding the side of grids most suitable for permanent adhesion.

The controversy is easily solved by examination of the surfaces involved. Grids are manufactured with a dull or rough side, and a shiny or smooth side. Epoxy sections exhibit a bumpy surface when viewed in the boat. Scanning electron microscopy images of epoxy sections without embedded material also reveal an uneven surface. Let us imagine a grid to be a single sided piece of sandpaper and the section to be a double sided piece of sandpaper. Sandpaper grips another piece of sandpaper much more readily than it does a smoothly polished metal surface. For the most secure adhesion of sections to grids, **SECTIONS SHOULD BE PICKED UP ON THE ROUGH SIDE OF THE GRID.**

Hildegard H. Crowley, Dept. of Biological Sciences, University of Denver, Denver, CO. 80208

TECHNICAL TIP

A Simple Method for Handling Grids

A simplified method for handling EM grids is described. This new method not only offers safety and identification of your samples but offers you improved handling, temporary storage, and identification of grids bearing ultrathin sections as well as a novel method for preparing bulk samples.

Refer to:

Gorycki, M.(1992). A Simple Method for Handling Grids. *Biotechnic & Histochemistry* 67/5, 313-314.

TECHNICAL TIP

Reaction of Ni and Cu Grids

How do Nickel and Copper Grids react with Periodic Acid?

Periodic Acid + Ni... Ni-Periodate + H₂
 Periodic Acid + Cu... Cu-Periodate + H₂

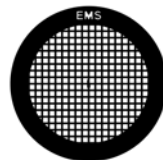
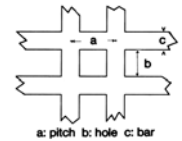
In this case you should use Gold Grids.

EMS Grids, Molybdenum Grids

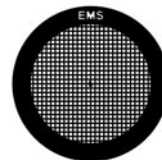
EMS Grids — Square Mesh and Oval Hole

Diameter: 3.05mm, **Thickness:** see chart

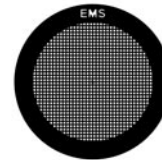
Material: Copper (Cu), Nickel (Ni), Gold (Au), Molybdenum (Mo)



200 mesh



300 mesh



400 mesh



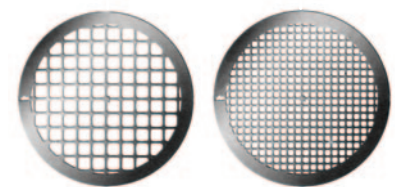
2x1 mm

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)	Thickness
EMS SQUARE MESH						
200 mesh	EMS200-Cu	100/vial	125	95	35	Up to 27µm, +/-5µm
	EMS200-Ni	100/vial	125	95	35	Up to 27µm, +/-5µm
	EMS200-Au	50/vial	125	95	35	11µm, +/-2µm
	EMS200-Mo	25/vial	125	95	35	25µm, +/-4µm
300 mesh	EMS300-Cu	100/vial	83	58	25	Up to 19µm, +/-5µm
	EMS300-Ni	100/vial	83	58	25	Up to 19µm, +/-5µm
	EMS300-Au	50/vial	83	58	25	10µm, +/-2µm
	EMS300-Mo	25/vial	83	58	25	25µm, +/-4µm
400 mesh	EMS400-Cu	100/vial	62	37	25	Up to 19µm, +/-5µm
	EMS400-Ni	100/vial	62	37	25	Up to 19µm, +/-5µm
	EMS400-Au	50/vial	62	37	25	9µm, +/-2µm
	EMS400-Mo	25/vial	62	37	25	25µm, +/-4µm
EMS OVAL HOLE						
2x1 mm	EMS2010-Cu	100/vial	—	2000x1000	—	27µm, +/-5µm
	EMS2010-Ni	100/vial	—	2000x1000	—	27µm, +/-5µm
	EMS2010-Au	50/vial	—	2000x1000	—	27 micron
	EMS2010-Mo	25/vial	—	2000x1000	—	25µm, +/-4µm

TEM Specimen Supports in Molybdenum

We have extended our range of TEM grid materials to include four types, which are now available in Molybdenum. The new products are manufactured using a process known as chemical 'milling' (etching) instead of the more familiar technique of 'electroforming' (deposition) that is used in the manufacture of copper, nickel and gold products. Molybdenum is used principally in applications where it's high temperature, hardness, expansion of coefficient and corrosion resistance characteristics are considered important. The material which is used has a purity of 99.9%.



G200-Mo
200# Grid

G100-Mo
100# Grid



G2010-Mo
2x1 Grid

G1000-Mo
1000 Micron Grid

Overall Diameter: 3.05mm
Rim Width: G200-Mo, G100-Mo: 0.225mm
Center Mark: G200-Mo, G100-Mo: Yes
Rim Mark: G200-Mo, G100-Mo: Yes
Molybdenum:
Symbol: Mo
Atomic number: 42
Melting point: 2617.0°C (2890.15°K, 4742.6°F)
Boiling point: 4612.0°C (4885.15°K, 8333.6°F)
Density: 10.22 g/cm³

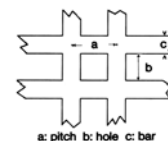
TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)	Thickness
200 mesh	G200-Mo	25/vial	125	90	35	25µm
100 mesh	G100-Mo	25/vial	250	205	45	25µm
2 x 1	G2010-Mo	25/vial	—	2 x 1 mm	—	50µm
1000 micron	G1000-Mo	25/vial	—	1000 µm	—	50µm

SPECIMEN SUPPORT GRIDS

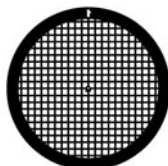
Gilder Grids

A reliable support specimen grid source. Features well-defined grid bars, maximum open area, and a matt/shiny side. Each grid is individually inspected. Newly introduced are copper grids with palladium plating. This plating offers better grid strength and avoids tarnishing.

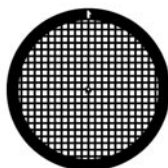


||| Gilder Standard Square Mesh

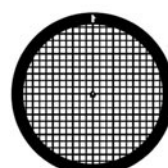
Diameter: 3.05mm
Thickness: 0.7 mil (18µm)
Material: Copper (Cu), Nickel (Ni), Gold (Au), Copper/Palladium (Cu/Pd=CP), Molybdenum (Mo)



G200



G200TH



G200TT

G200TH

A thickened version of the standard, G200TH with an assymmetric center. A mark on the rim allows for precise orientation of the grids.

G200TT

A combination of thin and thick bar grids, with a mark on the rim for orientation.

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
50 mesh	G50-Cu	100/vial	500	420	80
	G50-Ni	100/vial	500	420	80
	G50-Au	50/vial	500	420	80
75 mesh	G75-Cu	100/vial	340	285	55
	G75-Ni	100/vial	340	285	55
	G75-Au	50/vial	340	280	60
100 mesh	G100-Cu	100/vial	250	205	45
	G100-Ni	100/vial	250	205	45
	G100-CP	100/vial	250	205	45
	G100-Au	50/vial	250	200	50
	G100-Mo	25/vial	250	205	45
150 mesh	G150-Cu	100/vial	165	125	40
	G150-Ni	100/vial	165	125	40
	G150-CP	100/vial	165	125	40
	G150-Au	50/vial	165	125	40
175 mesh	G175-Cu	100/vial	145	108	37
	G175-Ni	100/vial	145	108	37
	G175-Au	50/vial	145	108	37
200 mesh	G200-Cu	100/vial	125	90	35
	G200-Ni	100/vial	125	90	35
	G200-CP	100/vial	125	90	35
	G200-Au	50/vial	125	90	35
	G200-Mo	25/vial	125	90	35
250 mesh	G250-Cu	100/vial	100	70	30
	G250-Ni	100/vial	100	70	30
	G250-Au	50/vial	100	70	30
200 mesh <i>see description above</i>	G200TH-Cu	100/vial	125	85	40
	G200TH-Ni	100/vial	125	85	40
200 mesh <i>see description above</i>	G200TT-Cu	100/vial	125	95	35-25
	G200TT-Ni	100/vial	125	95	35-25
300 mesh	G300-Cu	100/vial	83	58	25
	G300-Ni	100/vial	83	58	25
	G300-CP	100/vial	83	58	25
	G300-Au	50/vial	83	58	25
400 mesh	G400-Cu	100/vial	62	37	25
	G400-Ni	100/vial	62	37	25
	G400-CP	100/vial	62	37	25
	G400-Au	50/vial	62	37	25

||| Gilder Square Mesh with Handle

Diameter: 3.05mm,
Thickness: 0.7 mil (18µm)
Material: Copper (Cu), Nickel (Ni)



G200T

This grid is designed for ease of handling. The handle can also be easily removed if necessary. Just bend it over on a 90° angle.

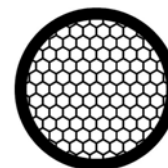
TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
200 mesh	G200T-Cu	100/vial	125	85	40
	G200T-Ni	100/vial	125	85	40

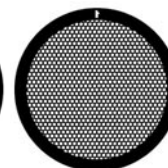
||| Gilder Standard Hexagonal Mesh

Diameter: 3.05mm,
Thickness: 0.7 mil (18µm)

Material: Copper (Cu), Nickel (Ni), Gold (Au)



G100H



G300H

TECHNICAL DATA

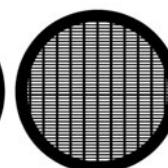
Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
50 mesh	G50H-Cu	100/vial	500	430	70
	G50H-Ni	100/vial	500	430	70
	G50H-Au	50/vial	500	430	70
75 mesh	G75H-Cu	100/vial	340	290	50
	G75H-Ni	100/vial	340	290	50
	G75H-Au	50/vial	340	290	50
100 mesh	G100H-Cu	100/vial	250	215	35
	G100H-Ni	100/vial	250	215	35
	G100H-Au	50/vial	250	205	45
200 mesh	G200H-Cu	100/vial	125	100	25
	G200H-Ni	100/vial	125	100	25
	G200H-Au	50/vial	125	100	25
300 mesh	G300H-Cu	100/vial	83	58	25
	G300H-Ni	100/vial	83	58	25
	G300H-Au	50/vial	83	58	25
400 mesh	G400H-Cu	100/vial	62	37	25
	G400H-Ni	100/vial	62	37	25
	G400H-Au	50/vial	62	37	25

||| Gilder Rectangular

Diameter: 3.05mm,
Thickness: 0.7 mil (18µm)
Material: Copper (Cu), Nickel (Ni)



G75/300



G100/400

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
G75/300	G7530-Cu	100/vial	340/83	290/58	50/25
	G7530-Ni	100/vial	340/83	290/58	50/25
G100/400	G1040-Cu	100/vial	250/62	205/37	45/25
	G1040-Ni	100/vial	250/62	205/37	45/25

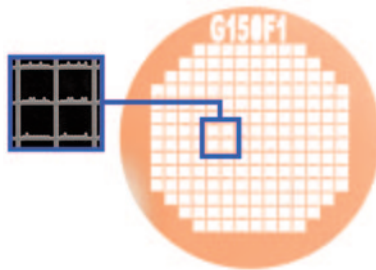
SPECIMEN SUPPORT GRIDS

Gilder Grids (continued)

III Gilder Finder Grids

III G150F1 Gilder Finder Grid

This grid has 172 complete square cells and each cell is identified by an 8 bit base 2 binary number symbol representation. 0 is represented by a short rounded pillar. There is no zero cell.



The first cell located at top left is binary 1, digit 1 is represented by a long pillar at the extreme right position on the bottom horizontal line of cell one: each individual subsequent cell is then easily identified. Lines/Inch ~150.

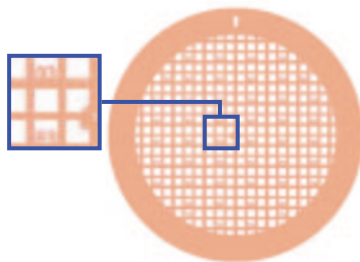
Diameter: 3.05mm, **Thickness:** 0.7 mil (18µm)
Material: Copper (Cu), Nickel (Ni), Gold (Au)

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
150 mesh	G150F1-Cu	100/vial	165 ± 0.5	~140 variable	~25 variable
	G150F1-Ni	100/vial	165 ± 0.5	140 variable	~25 variable
	G150F1-Au	50/vial	165 ± 0.5	140 variable	~25 variable

III G200F1 Gilder Finder Grid

Thick bars divide regions into 6 thin bar areas, which are identified by a numeric system.



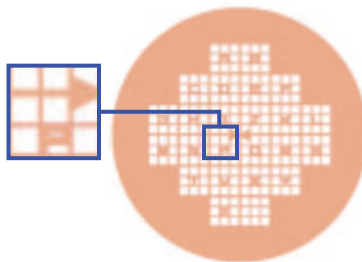
Diameter: 3.05mm,
Thickness: 0.7 mil (18µm)
Material: Copper (Cu), Nickel (Ni), Gold (Au), Copper/Palladium (Cu/Pd=CP)

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
200 mesh	G200F1-Cu	100/vial	125	90-100	35-12
	G200F1-Ni	100/vial	125	90-100	35-12
	G200F1-CP	100/vial	125	90-100	35-12
	G200F1-Au	50/vial	125	90-100	35-12

III G200F2 Gilder Finder Grid

Thick bars divide regions into 9 thin bar areas, which are identified by alphabetical letters located in the center of the grid.



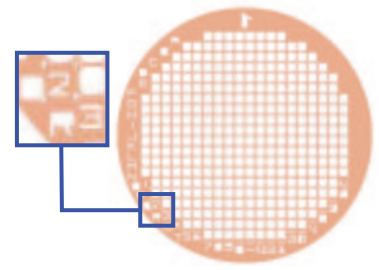
Diameter: 3.05mm,
Thickness: 0.7 mil (18µm)
Material: Copper (Cu), Nickel (Ni), Gold (Au), Copper/Palladium (Cu/Pd=CP)

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
200 mesh	G200F2-Cu	100/vial	125	106	25-12
	G200F2-Ni	100/vial	125	106	25-12
	G200F2-CP	100/vial	125	106	25-12
	G200F2-Au	50/vial	125	106	25-12

III G200HF3 Gilder Finder Grid

Each of the 322 grid squares, can be identified by reference to its unique combination of base 2 binary number and alphabet symbol (A-T). 0 is a short rounded solid pillar and 1 is a longer rounded solid pillar.



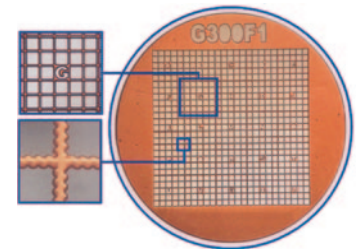
Diameter: 3.05mm, **Thickness:** 0.7 mil (18µm)
Material: Copper (Cu), Nickel (Ni), Gold (Au)

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
200 mesh	G200HF3-Cu	25/vial	125	—	—
	G200HF3-Ni	25/vial	125	—	—
	G200HF3-Au	25/vial	125	—	—

III G300F1 Gilder Finder Grid

A block of 625 (25 x 25) individual cells is divided into smaller blocks bounded by thicker crenellated bars. Each small block of 25 cells has a central alphabet letter from A to Y for identification purposes.



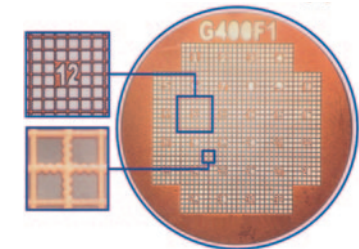
Diameter: 3.05mm, **Thickness:** 0.7 mil (18µm)
Material: Copper (Cu), Nickel (Ni), Gold (Au)

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
300 mesh	G300F1-Cu	100/vial	83	63	20
	G300F1-Ni	100/vial	83	63	20
	G300F1-Au	50/vial	83	63	20

III G400F1 Gilder Finder Grid

A block of 1152 (32 x 36) individual cells is divided into smaller blocks bounded by thicker crenellated bars. Each small block of 36 (6 x 6) cells has a central number from 1 to 32 for identification purposes.



Diameter: 3.05mm, **Thickness:** 0.7 mil (18µm)
Material: Copper (Cu), Nickel (Ni), Gold (Au)

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
400 mesh	G400F1-Cu	100/vial	62	47	15
	G400F1-Ni	100/vial	62	47	15
	G400F1-Au	50/vial	62	47	15

Gilder Grids (continued)

III Gilder Parallel Bars

Diameter: 3.05mm
Thickness: 0.7 mil (18µm)
Material: Copper (Cu), Nickel (Ni), Gold (Au)



TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
G50P	G50P-Cu	100/vial	500	416	84
	G50P-Ni	100/vial	500	416	84
	G50P-Au	50/vial	500	416	84
G50PB	G50PB-Cu	100/vial	500	416	84
	G50PB-Ni	100/vial	500	416	84
	G50PB-Au	50/vial	500	416	84
G75P	G75P-Cu	100/vial	340	270	70
	G75P-Ni	100/vial	340	270	70
	G75P-Au	50/vial	340	270	70
G75PB	G75PB-Cu	100/vial	340	270	70
	G75PB-Ni	100/vial	340	270	70
	G75PB-Au	50/vial	340	270	70
G100P	G100P-Cu	100/vial	250	185	65
	G100P-Ni	100/vial	250	185	65
	G100P-Au	50/vial	250	185	65
G100PB	G100PB-Cu	100/vial	250	185	65
	G100PB-Ni	100/vial	250	185	65
	G100PB-Au	50/vial	250	185	65
G150P	G150P-Cu	100/vial	165	115	50
	G150P-Ni	100/vial	165	115	50
	G150P-Au	50/vial	165	115	50
G150PB	G150PB-Cu	100/vial	165	115	50
	G150PB-Ni	100/vial	165	115	50
	G150PB-Au	50/vial	165	115	50
G200P	G200P-Cu	100/vial	125	80	45
	G200P-Ni	100/vial	125	80	45
	G200P-Au	50/vial	125	80	45
G200PB	G200PB-Cu	100/vial	125	80	45
	G200PB-Ni	100/vial	125	80	45
	G200PB-Au	100/vial	125	80	45
G300P	G300P-Cu	100/vial	83	48	35
	G300P-Ni	100/vial	83	48	35
	G300P-Au	50/vial	83	48	35
G300PB	G300PB-Cu	100/vial	83	48	35
	G300PB-Ni	100/vial	83	48	35
	G300PB-Au	50/vial	83	48	35
G400P	G400P-Cu	100/vial	62	22	40
	G400P-Ni	100/vial	62	22	40
	G400P-Au	50/vial	62	22	40
G400PB	G400PB-Cu	100/vial	62	22	40
	G400PB-Ni	100/vial	62	22	40
	G400PB-Au	50/vial	62	22	40

III Gilder Parallel Bars, Type GVPB

This new grid provides four levels of parallel bar specimen support. Quadrants are separated by crenelated bars. Larger areas may be viewed at lower magnification, depending on the appropriate specimen thickness.

NEW

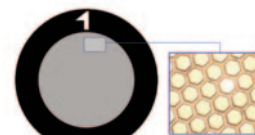


Quadrant	1	2	3	4
Lines/Inch	~100	~200	~200	~400
Pitch (± 0.5µ)	~250µm	~120µm	~83µm	~62µm
Bar Width	~65µm	~45µm	~40µm	~35µm
Hole Width	~185µm	~80µm	~43µm	~27µm

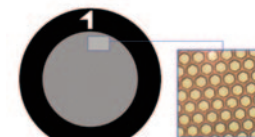
Type	Cat#	Packed	Description
GVPB	G-GVPB-Cu	100/vial	Parallel Bars, 4-Quadrant
	G-GVPB-Ni	100/vial	Parallel Bars, 4-Quadrant
	G-GVPB-Au	50/vial	Parallel Bars, 4-Quadrant

III Gilder High Mesh Values

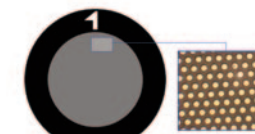
There is increasing interest in the use of high mesh value TEM specimen support grids in life science, materials sciences, semiconductor and nanotechnology. We introduce three new products designed to improve support for thin specimens and membranes. These have a high hole/bar ratios giving good transmission values.



G1000HH Hexagonal



G1500HH Hexagonal



G2000HA Hexagonal

Diameter: 3.05mm,
Thickness: 0.7 mil (18µm)
Mesh Diameter: 2mm,
Material: Copper (Cu), Nickel (Ni), Gold (Au).

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
G1000HH Hexagonal Mesh	G1000HH-Cu	25/vial	25	~19	~6
	G1000HH-Ni	25/vial	25	~19	~6
	G1000HH-Au	25/vial	25	~19	~6
G1500HH Hexagonal Mesh	G1500HH-Cu	15/vial	16.5	~10.5	~6
	G1500HH-Ni	15/vial	16.5	~10.5	~6
	G1500HH-Au	15/vial	16.5	~10.5	~6
G2000HA Circular Mesh	G2000HA-Cu	10/vial	12.5	~6.5	~6
	G2000HA-Ni	10/vial	12.5	~6.5	~6
	G2000HA-Au	10/vial	12.5	~6.5	~6

TECHNICAL TIP

The Preparation of Adhesive Coated Grids for Picking Up Carbon Film to Make Carbon Coated Grids

The following steps should be followed in the preparation of adhesive coated grids:

1. Submerge about 2" of Scotch clear tape (3M) into 10ml of Dichloroethane (Ethylene Dichloride); shake and discard the tape.
2. The solution now becomes "grid-glue"
3. Place the grids (dull side up) on a piece of filter paper (dust-free room).
4. Take a pipette and place a drop of "grid-glue" on top of each grid.
5. Let the grids dry.
6. The grids are now ready to pick up the carbon foil and make the carbon coated grids.

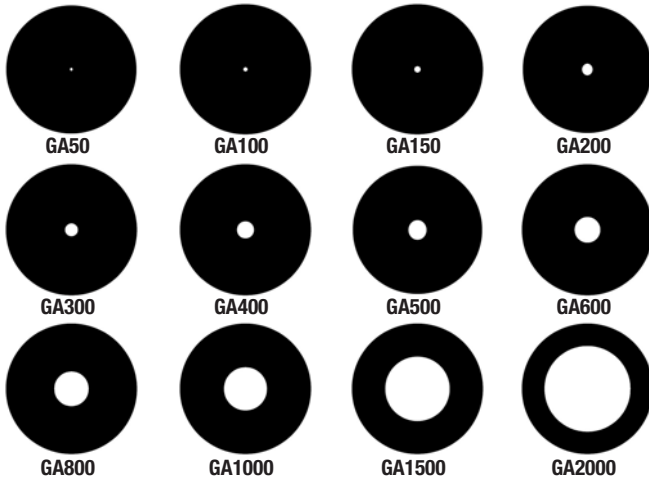
SPECIMEN SUPPORT GRIDS

Gilder Grids (continued)

||| Gilder Single Slot (Aperture Grids)

Diameter: 3.05mm, **Thickness:** 50µm

Material: Copper (Cu), Nickel (Ni), Gold (Au)

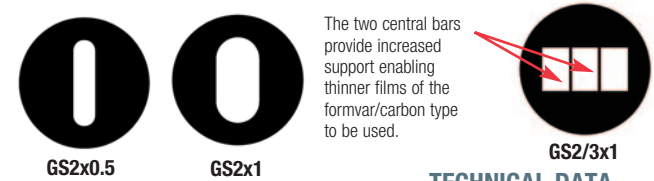


TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
GA50	GA50-Cu	100/vial	—	50	—
	GA50-Ni	100/vial	—	50	—
	GA50-Au	50/vial	—	50	—
GA75	GA75-Cu	100/vial	—	75	—
	GA75-Ni	100/vial	—	75	—
	GA75-Au	50/vial	—	75	—
GA100	GA100-Cu	100/vial	—	100	—
	GA100-Ni	100/vial	—	100	—
	GA100-Au	50/vial	—	100	—
GA150	GA150-Cu	100/vial	—	150	—
	GA150-Ni	100/vial	—	150	—
	GA150-Au	50/vial	—	150	—
GA200	GA200-Cu	100/vial	—	200	—
	GA200-Ni	100/vial	—	200	—
	GA200-Au	50/vial	—	200	—
GA300	GA300-Cu	100/vial	—	300	—
	GA300-Ni	100/vial	—	300	—
	GA300-Au	50/vial	—	300	—
GA400	GA400-Cu	100/vial	—	400	—
	GA400-Ni	100/vial	—	400	—
	GA400-Au	50/vial	—	400	—
GA500	GA500-Cu	100/vial	—	500	—
	GA500-Ni	100/vial	—	500	—
	GA500-Au	50/vial	—	500	—
GA600	GA600-Cu	100/vial	—	600	—
	GA600-Ni	100/vial	—	600	—
	GA600-Au	50/vial	—	600	—
GA800	GA800-Cu	100/vial	—	800	—
	GA800-Ni	100/vial	—	800	—
	GA800-Au	50/vial	—	800	—
GA1000	GA1000-Cu	100/vial	—	1000	—
	GA1000-Ni	100/vial	—	1000	—
	GA1000-Au	50/vial	—	1000	—
	GA1000-Mo	25/vial	—	1000	—
GA1500	GA1500-Cu	100/vial	—	1500	—
	GA1500-Ni	100/vial	—	1500	—
	GA1500-Au	50/vial	—	1500	—
GA2000	GA2000-Cu	100/vial	—	2000	—
	GA2000-Ni	100/vial	—	2000	—
	GA2000-Au	50/vial	—	2000	—

||| Gilder Single Slot (Oval Holes)

Diameter: 3.05mm, **Thickness:** 50µm **Material:** Copper (Cu), Nickel (Ni), Gold (Au), Molybdenum (Mo)



The two central bars provide increased support enabling thinner films of the formvar/carbon type to be used.

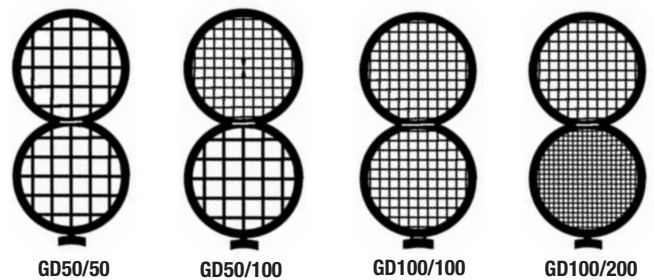
TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
GS2x0.5	G205-Cu	100/vial	—	2000x500	—
	G205-Ni	100/vial	—	2000x500	—
	G205-Au	50/vial	—	2000x500	—
GS2x1	G2010-Cu	100/vial	—	2000x1000	—
	G2010-Ni	100/vial	—	2000x1000	—
	G2010-Au	50/vial	—	2000x1000	—
	G2010-Mo	25/vial	—	2000x1000	—
GS2/3x1	G60610-Cu	100/vial	—	~606x1000	—
	G60610-Ni	100/vial	—	~606x1000	—
	G60610-Au	50/vial	—	~606x1000	—
	G60610-Mo	25/vial	—	~606x1000	—
GS1x0.2	G102-Cu	100/vial	—	1000x200	—
	G102-Ni	100/vial	—	1000x200	—
	G102-Au	50/vial	—	1000x200	—
GS1.5x0.3	G153-Cu	100/vial	—	1500x300	—
	G153-Ni	100/vial	—	1500x300	—
	G153-Au	50/vial	—	1500x300	—
GS2x0.75	G207-Cu	100/vial	—	2000x750	—
	G207-Ni	100/vial	—	2000x750	—
	G207-Au	50/vial	—	2000x750	—
GS2x1.5	G215-Cu	100/vial	—	2000x150	—
	G215-Ni	100/vial	—	2000x150	—
	G215-Au	50/vial	—	2000x150	—

||| Gilder Double Grids (Oyster)

These are used mostly in metallurgical applications for supporting thin metal foils. These grids have a curved securing tab which folds to the curvature of the 'sandwiched' grid. Four configurations are available.

Diameter: 3.05mm, **Thickness:** 0.7 mil (18µm) **Material:** Copper (Cu), Nickel (Ni), Gold (Au), Copper/Palladium (Cu/Pd=CP), Molybdenum (Mo)



TECHNICAL DATA

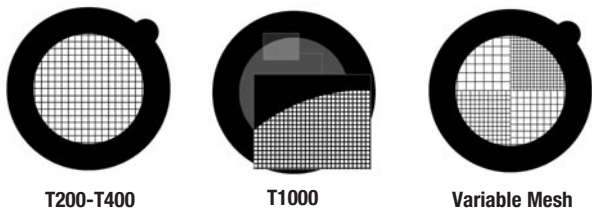
Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
GD50/50	GD50-Cu	100/vial	500/500	430/430	70/70
	GD50-Ni	100/vial	500/500	430/430	70/70
GD50/100	GD5010-Cu	100/vial	500/250	430/195	70/55
	GD5010-Ni	100/vial	500/250	430/195	70/55
GD100/100	GD1010-Cu	100/vial	250/250	200/200	50/50
	GD1010-Ni	100/vial	250/250	200/200	50/50
GD100/200	GD1020-Cu	100/vial	250/125	200/85	50/40
	GD1020-Ni	100/vial	250/125	200/85	50/40

Gilder Thin Bar Grids

Thin Bar Grids have been developed using a new technology to produce ultra-fine grids with thinner cross bars than regular grids. The result is equally firm specimen support but with 40% more open area for viewing maximum specimen surface area.

III Gilder Thin Bar Square Mesh

Diameter: 3.05mm, **Thickness:** 0.8 mil
Material: Copper (Cu), Nickel (Ni), Gold (Au)

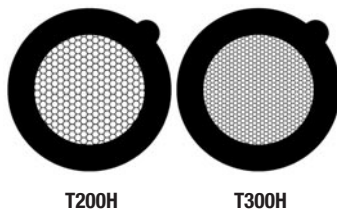


TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
200 mesh	T200-Cu	100/vial	125	113	12
	T200-Ni	100/vial	125	113	12
	T200-Au	25/vial	125	113	12
300 mesh	T300-Cu	100/vial	83	73	10
	T300-Ni	100/vial	83	73	10
	T300-Au	25/vial	83	73	10
400 mesh	T400-Cu	100/vial	62	54	8
	T400-Ni	100/vial	62	54	8
	T400-Au	25/vial	62	54	8
1000 mesh	T1000-Cu	25/vial	25	19	6
	T1000-Ni	25/vial	25	19	6
Variable Mesh	TVM-Cu	100/vial	Combined:150, 200, 300, 400 mesh. Same as above		
	TVM-Ni	100/vial			

III Gilder Thin Bar Hexagonal Mesh

Diameter: 3.05mm
Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni)



TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
200 mesh	T200H-Cu	100/vial	125	113	12
	T200H-Ni	100/vial	125	113	12
300 mesh	T300H-Cu	100/vial	83	73	10
	T300H-Ni	100/vial	83	73	10
400 mesh	T400H-Cu	100/vial	62	54	8
	T400H-Ni	100/vial	62	54	8
600 mesh	T600H-Cu	100/vial	37	29	8
	T600H-Ni	100/vial	37	29	8

III Gilder Thin Bar High Mesh Values

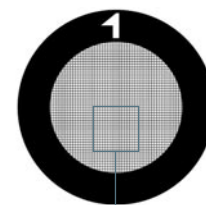
Revolutionary Specimen Support Grids

Diameter: 3.05mm,
Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni)

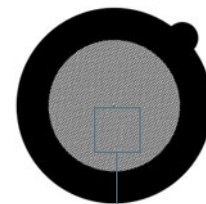
In addition to our square and hexagonal mesh Gilder Thin Bar Grids, we are now able to produce a very fine mesh that values up to 2,000 lines/inch. There is an increasing need in TEM for support thin films, routinely carbon, as thin as 1.5 - 2.0nm.

The pitch (the distance from the center of one bar to the center of the next bar) dimension in all grids remains constant, which allows them to be used as a lower magnification calibration aid.

Type T600HH (hexagonal) and T600HS (square) represent our efforts to reduce the grid bar width (only 5 microns) enabling more of the specimen to be viewed. All new types, apart from one side being shiny, the other matte, have a large asymmetrical mark in the rim which gives the identification of which side the specimen is on. Grids are 3.05mm overall diameter; 2.05mm mesh area diameter.



T601



T601H

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
600 mesh (square)	T601-Cu	100/vial	42	37	5
	T601-Ni	100/vial	42	37	5
600 mesh (hexagonal)	T601H-Cu	100/vial	42	37	5
	T601H-Ni	100/vial	42	37	5
1500 mesh (square)	T1500-Cu	15/vial	16.5	11.5	5
	T1500-Ni	15/vial	16.5	11.5	5
2000 mesh (square)	T2000-Cu	10/vial	12.5	7.5	5
	T2000-Ni	10/vial	12.5	7.5	5

TECHNICAL TIP

Removing a Charge from the Surface of Grids

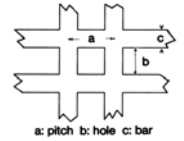
Sometimes when you are trying to pick up sections, they won't adhere to the grid surface. If you don't have time to glow discharge clean the grid surfaces, try this little trick. Dip the grids in distilled water for a moment and wick off the excess with filter paper. Let them dry while you are arranging your sections. Your sections should now adhere to the grid surface. Some labs soak the grids they will use for the day in distilled water until they are needed. If this procedure fails, reclean your grids with acetone or chloroform or glow discharge clean the grid surfaces.

Jeanette Killius, NEOUCOM, Rootstown, OH.

SPECIMEN SUPPORT GRIDS

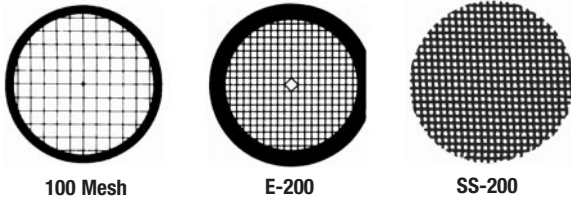
Veco Grids

With a wide variety of styles available, Veco Grids offer superior handling characteristics. Plus, with a 0.8 mil thickness, Veco Grids are the most rigid grids available.



III Square Mesh with Center Reference

Diameter: 3.05mm, **Thickness:** 0.8 mil
Material: Copper (Cu), Nickel (Ni), Gold (Au)



TECHNICAL DATA					
Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
50 mesh	0050-Cu	100/vial	500	450	50
	0050-Ni	100/vial	500	450	50
	0050-Au	50/vial	500	450	50
75 mesh	0075-Cu	100/vial	333	283	50
	0075-Ni	100/vial	333	283	50
	0075-Au	50/vial	333	283	50
100 mesh	0100-Cu	100/vial	250	200	50
	0100-Ni	100/vial	250	200	50
	0100-Au	50/vial	250	200	50
150 mesh	0150-Cu	100/vial	167	117	50
	0150-Ni	100/vial	167	117	50
	0150-Au	50/vial	167	117	50
200 mesh	0200-Cu	100/vial	125	85	40
	0200-Ni	100/vial	125	85	40
	0200-Au	50/vial	125	85	40
250 mesh	0250-Cu	100/vial	100	60	40
	0250-Ni	100/vial	100	60	40
300 mesh	0300-Cu	100/vial	83	45	38
	0300-Ni	100/vial	83	45	38
	0300-Au	50/vial	83	45	38
400 mesh	0400-Cu	100/vial	63	30	33
	0400-Ni	100/vial	63	30	33
	0400-Au	50/vial	63	30	33
E200	E200-Ni	100/vial	125	85	40
SS 200	0200-SS	100/vial	Punched from Stainless Steel Woven 200 mesh		

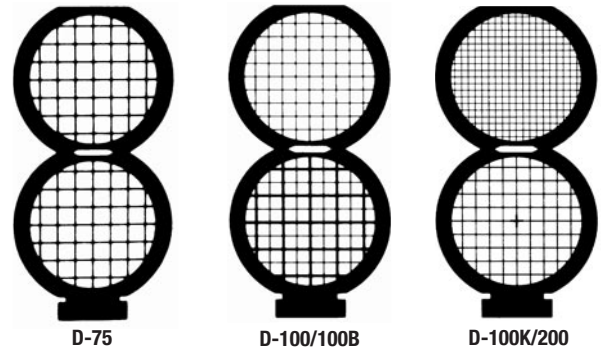
TECHNICAL TIP

On-Grid Enhancement

The use of nickel grids is recommended for on-grid enhancement, as nickel is relatively insensitive to silver enhancement. Gold or copper grids should not be used.

III Square Mesh Oyster Grids

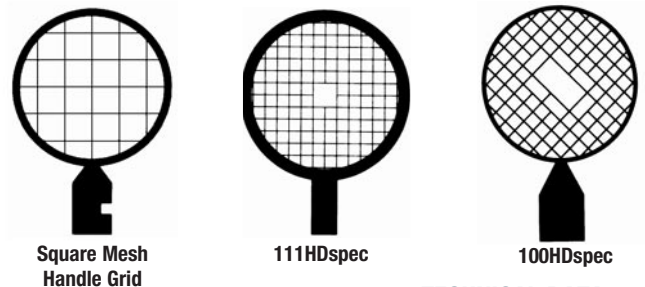
Diameter: 3.05mm, **Thickness:** 0.8 mil
Material: Copper (Cu), Nickel (Ni)



TECHNICAL DATA					
Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
D75	D75-Cu	100/vial	333	283	50
	D75-Ni	100/vial	333	283	50
D100/100B	D100B-Cu	100/vial	250x	200x	50x
			230/270	190	40/80
D100/100B	D100B-Ni	100/vial	250x	200x	50x
			230/270	190	40/80
D100K/200	D1002D-Cu	100/vial	250x	200x	50x
			125	85	40
D100K/200	D1002D-Ni	100/vial	250x	200x	50x
			125	85	40

III Square Mesh Handle Grids

Diameter: 3.05mm, **Thickness:** 0.8 mil **Material:** Copper (Cu), Nickel (Ni)

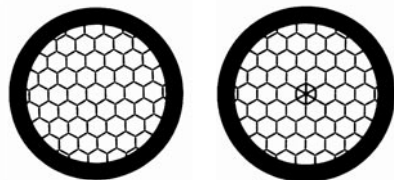


TECHNICAL DATA					
Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
100 mesh	HD100-Cu	100/vial	250	200	50
	HD100-Ni	100/vial	250	200	50
150 mesh	HD150-Cu	100/vial	167	117	50
	HD150-Ni	100/vial	167	117	50
200 mesh	HD200-Cu	100/vial	125	85	40
	HD200-Ni	100/vial	125	85	40
300 mesh	HD300-Cu	100/vial	83	45	38
	HD300-Ni	100/vial	83	45	38
400 mesh	HD400-Cu	100/vial	63	30	33
	HD400-Ni	100/vial	63	30	33
111HDspec	HD111S-Cu	100/vial	—	190	—
	HD111S-Ni	100/vial	—	190	—
100HDspec	HD100S-Cu	100/vial	—	200	—
	HD100S-Ni	100/vial	—	200	—

Veco Grids (continued)

Hexagonal Mesh

Diameter: 3.05mm, Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni), Gold (Au)



Hexagonal Mesh

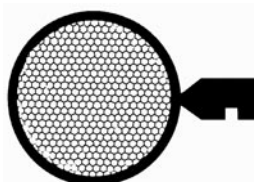
H111K Spec

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
H75 mesh	H075-Cu	100/vial	333	283	50
	H075-Ni	100/vial	333	283	50
H100 mesh	H100-Cu	100/vial	250	200	50
	H100-Ni	100/vial	250	200	50
H150 mesh	H150-Cu	100/vial	167	117	50
	H150-Ni	100/vial	167	117	50
H200 mesh	H200-Cu	100/vial	125	85	40
	H200-Ni	100/vial	125	85	40
	H200-Au	50/vial	125	85	40
H300 mesh	H300-Cu	100/vial	83	45	38
	H300-Ni	100/vial	83	45	38
	H300-Au	50/vial	83	45	38
H400 mesh	H400-Cu	100/vial	63	30	33
	H400-Ni	100/vial	63	30	33
H111KSpec	H111K-Cu	100/vial	-	185	-
	H111K-Ni	100/vial	-	185	-

Handle Grids
Hexagonal Mesh

Diameter: 3.05mm,
Thickness: 0.8 mil
Material: Copper (Cu),
Nickel (Ni), Gold (Au)



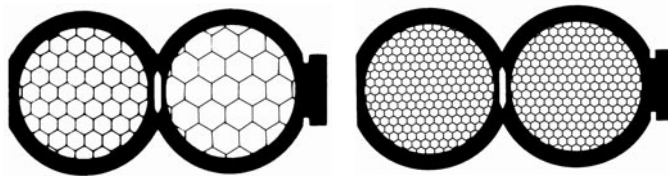
100-400 mesh

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
100 mesh	HD100H-Cu	100/vial	250	200	50
	HD100H-Ni	100/vial	250	200	50
150 mesh	HD150H-Cu	100/vial	167	117	50
	HD150H-Ni	100/vial	167	117	50
200 mesh	HD200H-Cu	100/vial	125	85	40
	HD200H-Ni	100/vial	125	85	40
300 mesh	HD300H-Cu	100/vial	83	45	38
	HD300H-Ni	100/vial	83	45	38
400 mesh	HD400H-Cu	100/vial	63	30	33
	HD400H-Ni	100/vial	63	30	33

Oyster Type Hexagonal Mesh

Diameter: 3.05mm, Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni), Gold (Au)



DH75/300

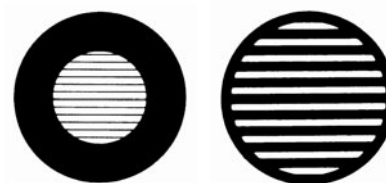
DH75-DH300

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
DH75/300	D753H-Cu	25/vial	333/83	293/45	50/38
	D753H-Ni	25/vial	333/83	293/45	50/38
DH75 mesh	D75H-Cu	25/vial	333	283	50
	D75H-Ni	25/vial	333	283	50
DH100 mesh	D100H-Cu	25/vial	250	200	50
	D100H-Ni	25/vial	250	200	50
DH200 mesh	D200H-Cu	25/vial	125	85	40
	D200H-Ni	25/vial	125	85	40
DH300 mesh	D300H-Cu	25/vial	83	45	38
	D300H-Ni	25/vial	83	45	38

Parallel Bar (R)

Diameter: 3.05mm, Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni)



R100-R300

RB90

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
R100	R100-Cu	100/vial	250	200	50
	R100-Ni	100/vial	250	200	50
R150	R150-Cu	100/vial	167	117	50
	R150-Ni	100/vial	167	117	50
R200	R200-Cu	100/vial	125	85	40
	R200-Ni	100/vial	125	85	40
R300	R300-Cu	100/vial	85	45	38
	R300-Ni	100/vial	85	45	38
RB90	RB90-Cu	100/vial	276	92	184
	RB90-Ni	100/vial	276	92	184

TECHNICAL TIP

A Simple Method for Handling Grids

A simplified method for handling EM grids is described. This new method not only offers safety and identification of your samples but offers you improved handling, temporary storage, and identification of grids bearing ultrathin sections as well as a novel method for preparing bulk samples.

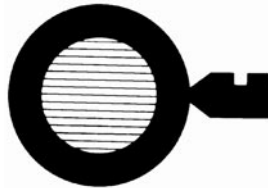
Gorycki, M.(1992). A Simple Method for Handling Grids. Biotechnic & Histochemistry 67/5, 313-314.

SPECIMEN SUPPORT GRIDS

Veco Grids (continued)

Parallel Bar Handle Grids

Diameter: 3.05mm,
Thickness: 0.8 mil
Material: Copper (Cu),
Nickel (Ni)



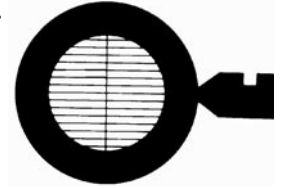
R100-R300

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
R100	HDR100-Cu	100/vial	250	200	50
	HDR100-Ni	100/vial	250	200	50
R200	HDR200-Cu	100/vial	125	85	40
	HDR200-Ni	100/vial	125	85	40
R300	HDR300-Cu	100/vial	85	45	38
	HDR300-Ni	100/vial	85	45	38

Parallel Bar with Divider Handle Grids

Diameter: 3.05mm, Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni)



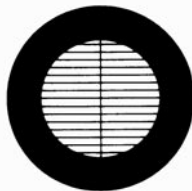
R100D-R300D

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
R100D	HDR100D-Cu	100/vial	250	200	50
	HDR100D-Ni	100/vial	250	200	50
R200D	HDR200D-Cu	100/vial	125	85	40
	HDR200D-Ni	100/vial	125	85	40
R300D	HDR300D-Cu	100/vial	85	45	38
	HDR300D-Ni	100/vial	85	45	38

Parallel Bar with Divider

Diameter: 3.05mm,
Thickness: 0.8 mil
Material: Copper (Cu),
Nickel (Ni)



R100D-R300D



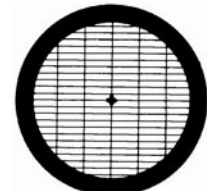
R100 Aspec

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
R100D	R100D-Cu	100/vial	250	200	50
	R100D-Ni	100/vial	250	200	50
R150D	R150D-Cu	100/vial	167	117	50
	R150D-Ni	100/vial	167	117	50
R200D	R200D-Cu	100/vial	125	85	40
	R200D-Ni	100/vial	125	85	40
R300D	R300D-Cu	100/vial	85	45	38
	R300D-Ni	100/vial	85	45	38
R100Aspec	R100As-Cu	100/vial	250	200	50
	R100As-Ni	100/vial	250	200	50

Slotted Patterns

Diameter: 3.05mm, Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni)



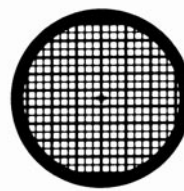
50/75-100/400

TECHNICAL DATA

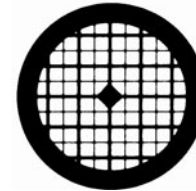
Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
50/75	575-Cu	100/vial	500/333	450/283	50
	575-Ni	100/vial	500/333	450/283	50
75/300	753-Cu	100/vial	300/83	293/43	40
	753-Ni	100/vial	300/83	293/43	40
100/400	1040-Cu	100/vial	250/63	212/25	38
	1040-Ni	100/vial	250/63	212/25	38

Thin and Thick Bars

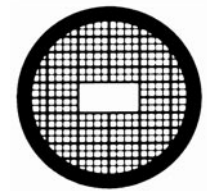
Diameter: 3.05mm, Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni)



100µk



100+y



GE 200

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
100µk	100S-Cu	100/vial	156/132	100	56/32
	100S-Ni	100/vial	156/132	100	56/32
100+y	100YM-Cu	100/vial	—	100	—
	100YM-Ni	100/vial	—	100	—
GE200	GE200-Ni	100/vial	125/145	80	45/65

Single slot:
1000x500

Sjostrand for Serial Sections

Diameter: 3.05mm, Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni)



R100/200A

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
R100/200A	R12CA-Cu	100/vial	250/125	120/75	130/50
	R12CA-Ni	100/vial	250/125	120/75	130/50

Veco Grids (continued)

Single Hole

Diameter: 3.05mm, Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni)



A600-A2000

TECHNICAL DATA

Type	Cat#	Packed	Hole Dia. (µm)
A600	0600-Cu	100/vial	600
	0600-Ni	100/vial	600
A800	0800-Cu	100/vial	800
	0800-Ni	100/vial	800
A1000	1000-Cu	100/vial	1000
	1000-Ni	100/vial	1000
A1500	1500-Cu	100/vial	1500
	1500-Ni	100/vial	1500
A2000	2000-Cu	100/vial	2000
	2000-Ni	100/vial	2000

Single Slot Oval

Diameter: 3.05mm, Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni)



L0.2x1.5-L2x1.5

TECHNICAL DATA

Type	Cat#	Packed	Hole Dia. (µm)
L0.2x1.5	0215-Cu	100/vial	200x1500
	0215-Ni	100/vial	200x1500
L2x1	2010-Cu	100/vial	2000x1000
	2010-Ni	100/vial	2000x1000
L2x1.5	2015-Cu	100/vial	2000x1500
	2015-Ni	100/vial	2000x1500

Oyster

Diameter: 3.05mm, Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni)



DL2X1

TECHNICAL DATA

Type	Cat#	Packed	Hole Dia. (µm)
DL 2x1	DL2010-Cu	25/vial	2000x1000
	DL2010-Ni	25/vial	2000x1000

Special Shapes

Diameter: 3.05mm, Thickness: 0.8 mil, Material: Copper (Cu)



Z1600



EA1500



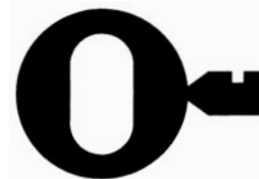
Z600

TECHNICAL DATA

Type	Cat#	Packed	Hole Dia. (µm)
Z1600	Z1600-Cu	100/vial	inner: 1600, outer: 1900 width:150
EA1500	EA1500-Cu	100/vial	1500
Z600	Z600-Cu	100/vial	inner: 600, outer: 900 width: 150

Handle

Diameter: 3.05mm, Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni)



HDL2X1

TECHNICAL DATA

Type	Cat#	Packed	Hole Dia. (µm)
HDL2x1	HD2010-Cu	100/vial	2000x1000
	HD2010-Ni	100/vial	2000x1000

Rectangular

Diameter: 3.05mm, Thickness: 0.8 mil
Material: Copper (Cu), Nickel (Ni)



L2.X0.6-L0.2X0.5

TECHNICAL DATA

Type	Cat#	Packed	Hole Dia. (µm)
L2x0.6	0620-Cu	100/vial	2000x600
	0620-Ni	100/vial	2000x600
L0.2x1	1002-Cu	100/vial	200x1000
	1002-Ni	100/vial	200x1000
L0.2x0.5	0502-Cu	100/vial	200x500
	0502-Ni	100/vial	200x500

TECHNICAL TIP

The Preparation of Adhesive Coated Grids for Picking Up Carbon Film to Make Carbon Coated Grids

The following steps should be followed in the preparation of adhesive coated grids:

1. Submerge about 2" of Scotch clear tape (3M) into 10ml of Dichloroethane (Ethylene Dichloride); shake and discard the tape.
2. The solution now becomes "grid-glue"
3. Place the grids (dull side up) on a piece of filter paper (dust-free room).
4. Take a pipette and place a drop of "grid-glue" on top of each grid.
5. Let the grids dry.
6. The grids are now ready to pick up the carbon foil and make the carbon coated grids.

SPECIMEN SUPPORT GRIDS

Maxtaform Grids

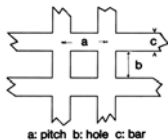
High Grade Maxtaform Grids with clean and smooth edges, firm support, and a large open area. Our copper grids are available with one surface coated with inert Rhodium. This coating will eliminate tarnishing, give side identification, and reduce the bar thickness.

Square Mesh

Diameter: 3.05mm

Thickness: 0.75 mil

Material: Copper/Rhodium (Cu/Rh = CR), Nickel (Ni), Gold (Au)



100-400 mesh



500-600 mesh



2x1 mm

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
SQUARE MESH					
100 mesh	M100-CR	100/vial	254	213	41
	M100-Ni	100/vial	254	213	41
150 mesh	M150-CR	100/vial	165	131	34
	M150-Ni	100/vial	165	131	34
	M150-Au	100/vial	165	131	34
200 mesh	M200-CR	100/vial	127	103	24
	M200-Ni	100/vial	127	103	24
	M200-Au	100/vial	127	103	24
300 mesh	M300-CR	100/vial	84	61	23
	M300-Ni	100/vial	84	61	23
	M300-Au	100/vial	84	61	23
400 mesh	M400-CR	100/vial	63	43	20
	M400-Ni	100/vial	63	43	20
	M400-Au	100/vial	63	43	20
500 mesh	M500-Cu	100/vial	51	28	23
	M500-Ni	100/vial	51	28	23
	M500-Au	25/vial	51	28	23
600 mesh	M600-CR	100/vial	41	26	15
	M600-Cu	100/vial	41	26	15
	M600-Ni	100/vial	41	26	15
OVAL HOLE					
2x1 mm	M2010-CR	100/vial	—	2000x1000	—
	M2010-Ni	100/vial	—	2000x1000	—
	M2010-Au	25/vial	—	2000x1000	—

Oval Hole

Diameter: 3.05mm, **Thickness:** 0.75 mil

Material: Copper/Rhodium (Cu/Rh = CR), Nickel (Ni), Gold (Au)

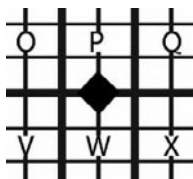
Maxtaform Finder Grids

Maxtaform grids with reference patterns are of the highest consistent quality, with a wide choice to choose from to suit all your particular needs.

London Finder

H 2, Pitch 127µ, 200 mesh

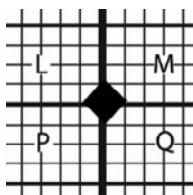
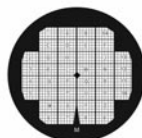
LF200-Cu	100/vial
LF200-Ni	100/vial
LF200-Au	100/vial



London Finder

H 7, Pitch 63µ, 400 mesh

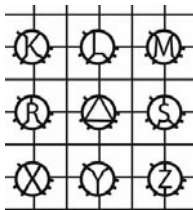
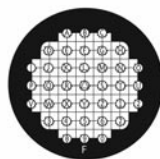
LF400-Cu	100/vial
LF400-Ni	100/vial
LF400-Au	100/vial



London Finder

H 15, Pitch 188µ, 135 mesh

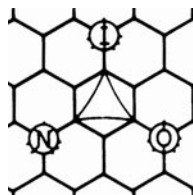
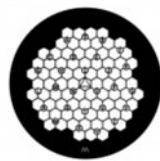
LF135-Cu	100/vial
LF135-Ni	100/vial



London Honeycomb

H 6, Pitch 235µ, Honeycomb

LH200-Cu	100/vial
LH200-Ni	100/vial



Maxtaform Specialist Grids

3 mm diameter. These grids fill all your special needs.

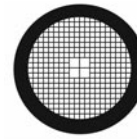
H 9, Pitch 508µ, 50 mesh

H9Spec-Cu	100/vial
H9Spec-Ni	100/vial



HF14, Pitch 127µ, 200 mesh

HF14Spec-Cu	100/vial
HF14Spec-Ni	100/vial



H 1, Pitch 127µ, 200 mesh

H1Spec-Cu	100/vial
H1Spec-Ni	100/vial



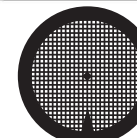
H 12 Folding, Pitch 126µ, 200 mesh

H12Spec-Cu	25/vial
H12Spec-Ni	25/vial



H 4, Pitch 63µ, 400 mesh

H4Spec-Cu	100/vial
H4Spec-Ni	100/vial



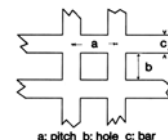
SPECIMEN SUPPORT GRIDS

EMBRA Grids

Diameter: 3.05mm, **Thickness:** 16µm for meshed and 5-20 µm for oval hole grids*

Material: Copper (Cu), Nickel (Ni), Gold (Au), Stainless Steel (SS), Titanium (Ti), Molybdenum (Mo), Aluminum (Al)

EMBRA electroformed grids combine a high open area with a rigid construction which allows for relatively easy handling. We offer these grids in a series of hard to find materials, which are not available from other manufacturers. They are as follows: Stainless Steel (SS), Titanium (Ti), Molybdenum (Mo), and Aluminum (Al)



Square Mesh



100 mesh

200 mesh

300 mesh

Type	Cat#	Pack	Open Area
100 mesh	E100-SS	25/vial	65%
	E100-Ti	25/vial	65%
	E100-Mo	25/vial	65%
	E100-Al	25/vial	65%
200 mesh	E200-SS	25/vial	50%
	E200-Ti	25/vial	50%
	E200-Mo	25/vial	50%
	E200-Al	25/vial	50%
300 mesh	E300-Ti	25/vial	40%
	E300-Mo	25/vial	40%
	E300-Al	25/vial	40%

Oval Slot



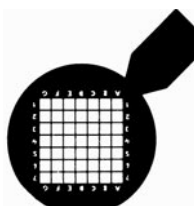
0.4-2mm

2x1mm

Type	Cat#	Pack	Open Area
0.4x2mm	E0420-SS	25/vial	—
	E0420-Ti	25/vial	—
	E0420-Mo	25/vial	—
	E0420-Al	25/vial	—
2x1mm	E2010-SS	25/vial	—
	E2010-Ti	25/vial	—
	E2010-Mo	25/vial	—
	E2010-Al	25/vial	—

Coordinator

Standard 3.05mm grids, with a handle. They are available in copper and nickel.

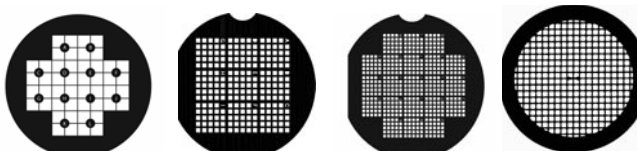


100 mesh

Type	Cat#	Pack	Open Area
100 mesh	EC100-Cu	100/vial	—
	EC100-Ni	100/vial	—
200 mesh	EC200-Cu	100/vial	—
	EC200-Ni	100/vial	—
300 mesh	EC300-Cu	100/vial	—
	EC300-Ni	100/vial	—

Finder

Standard 3.05mm diameter grids which have one straight and one round cut out from the rim which assists in the orientation of the grid. They are available in Copper, Nickel, and Gold Grids.



100 mesh

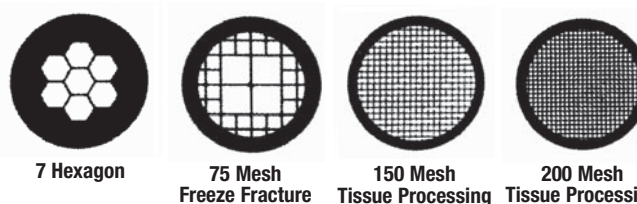
200 mesh

300 mesh

400 mesh

Type	Cat#	Pack	Open Area
100 mesh	EF100-Cu	100/vial	—
	EF100-Ni	100/vial	—
200 mesh	EF200-Cu	100/vial	—
	EF200-Ni	100/vial	—
	EF200-Au	25/vial	—
300 mesh	EF300-Cu	100/vial	—
	EF300-Ni	100/vial	—
	EF300-Au	25/vial	—
400 mesh	EF400-Cu	100/vial	—
	EF400-Ni	100/vial	—
	EF400-Au	25/vial	—

Selective Grids

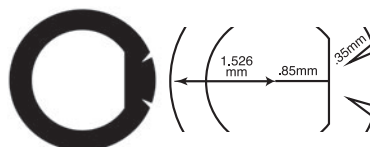


7 Hexagon

75 Mesh Freeze Fracture

150 Mesh Tissue Processing

200 Mesh Tissue Processing



CHIEN Grid

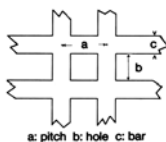
Type	Cat#	Pack	Open Area
7 Hexagon			
7-Hex	E7HEX-Cu	100/vial	—
7-Hex	E7HEX-Ni	100/vial	—
Freeze Fracture			
75FF	E75FF-Cu	100/vial	—
75FF	E75FF-Ni	100/vial	—
Tissue Processing			
6G150	ETP150-Cu	100/vial	—
6G150	ETP150-Ni	100/vial	—
6G200	ETP200-Cu	100/vial	—
6G200	ETP200-Ni	100/vial	—
Chien Grids			
9G20H	EC20H-Cu	100/vial	—
9G20H	EC20H-Ni	100/vial	—

* Reference: Chien R, Van de Velde R, Heusser R: Simultaneous Ultramicrotomy of multiple areas and examination of ribbons on one new grid. Proc. 43rd Annual Meeting, Elec. Micro. Soc. Amer., G W Bailey, ed, San Francisco Press, 460 (1985). Galey FR, Nilson SEG: A new method for transferring sections from the liquid surface of the trough through staining solutions to the supporting film of a grid. J. Ultrastruct. Res., 14, (1966), 405-410.

SPECIMEN SUPPORT GRIDS

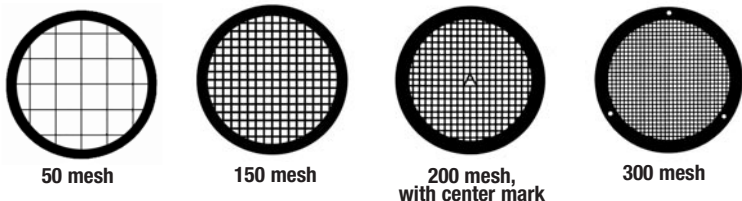
Athene Grids

EMS is pleased to now offer the Athene range of grids, renowned for decades for the highest quality standards, exceptionally refined grid bars, and good handling characteristics.



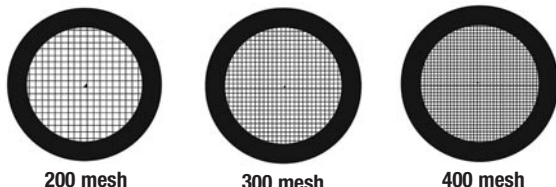
Square Mesh

Diameter: 3.05mm, **Material:** Copper (Cu), Nickel (Ni), Gold (Au)



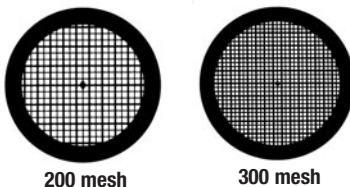
Thin Bar with Center Mark

Diameter: 3.05mm, **Material:** Copper (Cu), Nickel (Ni)



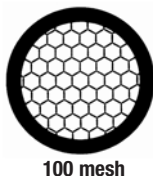
Thick and Thin Bar with Center Mark

Diameter: 3.05mm, **Material:** Copper (Cu)



Hexagonal Mesh

Diameter: 3.05mm, **Material:** Copper (Cu), Nickel (Ni)



Slotted

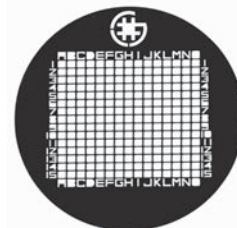
Diameter: 3.05mm, **Material:** Copper (Cu)



Index Grids

Alpha Numeric Index Grid

By employing a rectangular mesh the support value of the grid has been increased, offering a value intermediate between the most commonly used grid (200 Lines/" and 300 Lines/"). Each grid rectangle is asymmetrical having different outlines in all four corners. This allows for the orientation of the grid to be determined at microscopic levels. The index feature enables the position of each grid to be identified with reference to the letters A-O along the horizontal axis and the numbers 1-15 along the vertical axis. The logo in the rim allows for precise orientation and aids in the identification of each side. Grids are available in Copper, Copper/Palladium, Nickel, and Gold.



SPECIFICATIONS:

	Horizontal Axis:	Vertical Axis:
Mesh:	200 Lines/"	250 Lines/"
Pitch:	125 microns	105 microns
Bar Width:	20 microns	15 microns
Hole Width:	105 microns	90 microns
Overall Diameter:	3.05 mm	3.05 mm

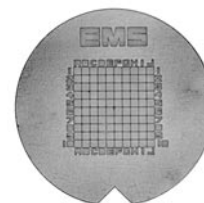
CORNER OUTLINE WITH REFERENCE TO LOGO IN THE RIM:

Top Right	Right Angle
Top Left	Inverted Quadrant
Bottom Right	Diagonal Line
Bottom Left	Quadrant

Cat. No.	Description	Pack
G200F4-Cu	Alpha/Numeric Index Grid, Copper	100/vial
G200F4-CP	Alpha/Numeric Index Grid, Copper/Palladium	100/vial
G200F4-Ni	Alpha/Numeric Index Grid, Nickel	100/vial
G200F4-Au	Alpha/Numeric Index Grid, Gold	50/vial

Asbestos Analysis Index Grids

Our unique index grids for all of your microscopy work. These grids are manufactured in the strictest accordance to meet AHERA requirements.



SPECIFICATIONS:

Overall Diameter	3.05mm
Mesh	200 lines/"
Pitch	125 microns
Bar Width	10 microns +/- 2 microns
Hole Width	115 microns +/- 2 microns
Index Identification	Horizontal: A-J, Vertical: 1-10

EMS Logo in Rim
Asymmetrical Allows for precise repeat location
Cut Out In Rim and aids in side differentiation

Cat. No.	Description	Pack
G200EMSIND-Cu	Asbestos Analysis Index Grids, Copper	100/vial
G200EMSIND-Ni	Asbestos Analysis Index Grids, Nickel	100/vial

TECHNICAL DATA

Type	Cat#	Packed	Pitch (µm)	Hole (µm)	Bar (µm)
SQUARE MESH					
50 mesh	A50-Cu	100/vial	—	450	—
150 mesh	A150-Cu	100/vial	—	150	—
200 mesh	A200-Cu	100/vial	—	100	27
	A200-Ni	100/vial	—	100	27
300 mesh	A300-Cu	100/vial	—	70	—
	A300-Ni	100/vial	—	70	—
400 mesh	A400-Cu	100/vial	—	45	—
SQUARE MESH WITH CENTER MARK					
200 mesh	AC200-Cu	100/vial	—	100	27
	AC200-Au	100/vial	—	100	27
THIN BAR WITH CENTER MARK					
200 mesh	AT200-Cu	100/vial	—	—	10
	AT200-Ni	100/vial	—	—	10
300 mesh	AT300-Cu	100/vial	—	—	10
	AT300-Ni	100/vial	—	—	10
400 mesh	AT400-Cu	100/vial	—	—	10
THICK AND THIN BAR WITH CENTER MARK					
200 mesh	ATT200-Cu	100/vial	—	150	—
300 mesh	ATT300-Cu	100/vial	—	75	—
HEXAGONAL MESH					
100 mesh	AH100-Cu	100/vial	—	240	—
	AH100-Ni	100/vial	—	240	—
400 mesh	AH400-Cu	100/vial	—	240	—
SLOTTED					
Multiple Slots	AS-Cu	100/vial	—	350-700	—

III SynapTek™ Grids

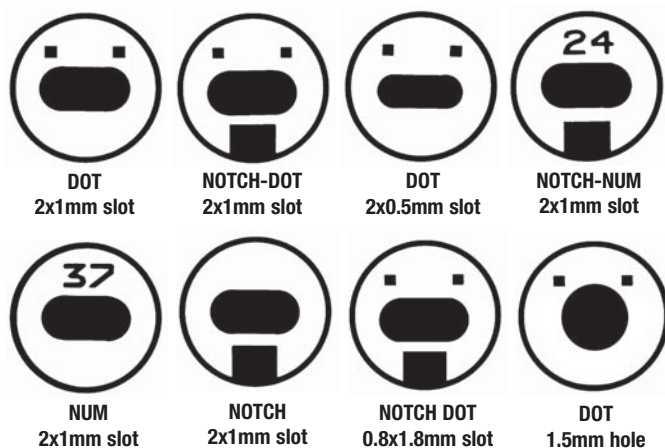
Very reliable under the electron beam- Synaptek® unflexible grids, made of a special alloy (Beryllium-Copper). Offers extreme stability for coating with support film. 4 mil thick (100µm), 3.05mm diameter, this standard 2x1mm oval slot grids are contamination free and reusable after cleaning. 0.5x2mm oval slots are also available.

NUM grids: Numbered grids are in random order. Numbers may be duplicated.

DOT grids: 2 dots are marked on one side of the grid for identification. Dots are visible to the naked eye.

NOTCH grids: A mark, stamped on one side of the grid to facilitate the handling of the grids. Notch is available with NUM or DOT grids.

GILDED grids: completely Gold-Plated grids, suitable for immunology research, autoradiography, as well as special needs.



Cat. No.	Description	Pack
S2010-DOT	DOT, 2 x 1 mm slot	100/vial
S2010-NUM	NUM, 2 x 1 mm slot	100/vial
S2010-NOTCH	NOTCH, 2 x 1 mm slot	100/vial
S2010-ND	NOTCH-DOT, 2 x 1 mm slot	100/vial
S2010-NN	NOTCH-NUM, 2 x 1 mm slot	100/vial
SG2010-NN	GILDED NOTCH-NUM, 2 x 1 mm slot, Gold Plated	100/vial
S2005-DOT	DOT, 0.5 x 2 mm slot	100/vial
S1808-ND	NOTCH-DOT, 0.8 x 1.8 mm slot	100/vial
S1020-NI	Ni-NOTCH-DOT, 1 x 2 mm slot, Nickel	100/vial
S1500-DOT	DOT, 1.5 mm hole	100/vial
S1500NI-DOT	Ni-DOT, 1.5 mm hole, Nickel	100/vial
S1500MO-DOT	Mo-DOT, 1.5 mm hole, Molybdenum, Thickness of 75µm (3 mil)	25/vial

III Tomography Grids

This 1.5mm square, 300 mesh grid is made from copper and is for use with Fischione tomography specimen holders. The size allows for further tilt in TEMs with small pole piece holes. An identification mark and the square shape give easy reference when rotated past 90°.



Cat. No.	Description	Pack
74357	Copper Tomography Grid, 300 mesh	50/pk

Support Films on Tomography Grids

74357-01	Lacey Carbon on Copper Tomography Grid	25/pk
74357-02	Lacey Carbon on Copper Tomography Grid	50/pk
74357-03	Carbon Film on Copper Tomography Grid	25/pk
74357-04	Carbon Film on Copper Tomography Grid	50/pk

TECHNICAL TIP

A Fool-proof Method for Mounting Serial Sections on Single Hole Grids

I did serial sectioning for years on large single hole grids using a very simple technique that made the potential problems of film thickness, wrinkles and section loss very minor. I was not the original developer of the method and do not remember who originally gave it to me. It goes as follows:

1) Have your machine shop cut some thin pieces of Plexiglas into the size of glass slides. At one end, drill about a dozen holes, roughly 5mm in diameter, in an area about the size of a formvar film cast on glass slides. These slides will serve as your template for holding your films.

2) Cast the formvar films onto glass slides using your normal method. Usually a good silver film, not gray, will work fine I routinely used 0.2% formvar in dichloroethane when casting by immersing the slide into the solution in a small jar, etc. We now use a film caster that lets us hold the slide in the dichloroethane vapors after lowering the formvar solution level. This method tends to give you thinner films consistently so the correct solution percentage and timing would have to be redetermined.

3) Float the film off the glass slide and pick it up with the Plexiglas slide so the film covers the holes. Then draw the water out of the holes by pressing the plastic slide down onto filter paper, or using small pieces of filter paper and capillary action to draw the water out of individual holes. The films should hold nicely over the holes in the slide. Store slides until needed.

4) Next, cut your sections using a block diameter that is fairly similar to the size of the slit in the grid. Pick up the sections on UNCOATED grids by gently lowering the grid to the surface of the knife boat. I put the dull side down on the premise that the rough surface would grab the film better during step 6. The surface tension of the water will hold the sections in the grid opening. Transfer the grid to a droplet water until you have finished sectioning. Do invert grid. It important the of grid (shiny side) stay dry so that the grid will float on all subsequent solutions.

5) Transfer the grid + sections + water droplet to a drop of stain. A small amount of water will be transferred but this will not interfere with staining. If you are concerned about the dilution effect, increase your staining time slightly. Allow the section to stain, then wash by transferring through a series of droplets of clean water. Continue to if desired and wash the same way. Never let the grid dry. There is minimum problem with stain precipitation if you use very clean water and transfer the grid through a sufficient number of water droplets (6-12 recommended).

6) The final step is to transfer the grid to a film suspended over the hole in a Plexiglas slide and let it dry down. The sections will now be stuck to the film with NO wrinkles and minimum breakage. When ready to view, just punch out around the grid with the tip of your forceps, grab the grid and insert into the microscope.

Believe me...the sections will still be there at the end!

I found that as long as the sections cover a substantial portion of the open area of the grid, carbon coating was not essential. I used to do 50-100 grids worth of serial sections without losing any. The films on the plastic slides would hold for months so I could make a lot and store until needed.

Previously Published in: Sherman, D.M. (1998) A Full-proof Method for Mounting Serial Sections on Single Hole Grids. MSA Technologist's Forum Newsletter 16:2

III Plexiglas Microscope Slides

These plexiglass slides are 3 x 1" (75-25mm) and 1 mm thick. They prevent wrinkling and section loss while mounting sections on grids. The procedure is simple (see above).

Cat. No.	Description	Qty.
71891-10	Plexiglass Microscope Slides	5/pk



LIFT-OUT GRIDS

Omniprobe TEM Grids & Accessories

This section is dedicated to the accessories and consumables from the Omniprobe family of Nanomanipulation Systems, including: *AutoProbe™ 200, AutoProbe™ 250, AutoProbe™ 300, Short-Cut™, OmniGIS™ and SST™ 400-1.*

Omniprobe TEM Grid Comparison Chart

Part Number	Number of Posts	Material	Thickness (Nominal) Microns	Nominal Post Downset Microns	Unique Feature
75964-01	3	Copper	30	10	—
75964-02	3	Molybdenum	30	10	Top Downset only
75964-03	0	Beryllium	25	N/A	Half Ring
75964-04	5	Copper	40	10	5th Post is E
75964-05	4	Copper	30	10	—
75964-06	4	Molybdenum	30	10	Top DS Only
75964-07	3	Copper	30	5	Side Access
75964-08	3	Copper	30	5	—
75964-09	5	Copper	35	5	5th Post is "E"
75964-10	4	Copper	30	5	—

III Copper or Molybdenum Lift-Out Grids

Custom copper or molybdenum lift-out grids specifically designed for in-situ lift-out. These grids include multiple indexed mounting locations with both vertical bars and "V" shaped attachment surfaces. 3mm diameter.

Cat. No.	Description	Pack
75964-01	Copper Lift-Out Grids	100/vial
75964-02	Molybdenum Lift-Out Grids	25/vial



75964-01



75964-02

III Beryllium Haft-Ring Grids

Custom beryllium haft ring grids. 3mm diameter.

Cat. No.	Description	Pack
75964-03	Beryllium Haft Ring Grids	10/pk



75964-03

III Copper 5-Post Lift-Out Grids

Custom copper 5-post lift-out grids specially designed for in-situ lift-out. These grids include multiple indexed mounting locations, all with vertical bars attachment surfaces. Now with lower profile sides for easier access to outermost posts. 3mm diameter.

Cat. No.	Description	Pack
75964-04	Copper 5-Post Lift-Out Grids	100/vial



75964-04

III Copper or Molybdenum 4-Post Lift-Out Grids

Custom copper or molybdenum 4-post lift-out grids specially designed for in-situ lift-out. These grids include multiple indexed mounting locations, two with vertical bars attachment surfaces and two with "V" shaped alignment surfaces. Sides have lower profile for easier access to outermost posts. 3mm diameter.

Cat. No.	Description	Pack
75964-05	Copper 4-Post Lift-Out Grids	100/vial
75964-06	Mo 4-Post Lift-Out Grids	25/vial



75964-05



75964-06

III Copper 3-Post Lift-Out Grids, Side Access

3 post copper lift-out grids, similar to 75964-01, in design but 35 micron thick with 1 edge lower for easy access. Packaged in glass vials

Cat. No.	Description	Pack
75964-07	Copper 3-Post Lift-Out Grids, Side Access	100/vial



75964-07

III Copper 3-Post Lift-Out Grids, Shallow Downset

3 post copper lift-out grids specifically designed for in-situ lift-out. These grids include multiple indexed mounting locations with both vertical bar and "V" shaped attachment surfaces. These grids have a shallower downset and slightly wider center post than 75964-01. Packaged in glass vials.

Cat. No.	Description	Pack
75964-08	Copper 3-Post Lift-Out Grids, Shallow Downset	100/box



75964-08

III Copper 5-Post Lift-Out Grids

5 post copper lift-out grids specifically designed for in-situ lift-out. These grids include multiple indexed mounting locations, all with vertical bar attachment surfaces. Now with lower profile sides for easier access to outermost posts. 3mm dia. Packaged in glass vials.

Cat. No.	Description	Pack
75964-09	Copper 5-Post Lift-Out Grids	100/box



75964-09

III Copper 4-Post Lift-Out Grids

4 post copper lift-out grids specifically designed for in-situ lift-out. These grids include multiple indexed mounting locations, two with vertical bar attachment surfaces and two with "V" shaped alignment surfaces. Sides have lower profile for easier access to outermost posts. 3mm dia. Packaged in plastic vials.

Cat. No.	Description	Pack
75964-10	Copper 4-Post Lift-Out Grids	100/box



75964-10

Omniprobe TEM Grids & Accessories (continued)

Short-Cut™ Coupons

Frontside Thinning, 45°

Frontside Thinning, 45°, TEM sample grid coupon designed specially for use in the Short-Cut™ tool. The center portion is a standard 3 mm grid into which the sample loaded needle is swaged and cut 45°. Available in two versions: One is made from pure copper and the other is molybdenum coated copper.



Cat. No.	Description	Qty.
75974-Cu	Frontside Thinning Copper, 45°	20/pk
75974-Mo	Frontside Thinning Mo/Cu, 45°	20/pk

Backside Thinning, 45°

Backside Thinning, 45°, TEM sample grid coupon designed specially for use in the Short-Cut™ tool. The center portion is a standard 3 mm grid into which the sample loaded needle is swaged and cut 45°. Available in two versions: One made from pure copper and the Other is molybdenum coated copper.



Cat. No.	Description	Qty.
75975-Cu	Backside Thinning Copper, 45°	20/pk
75975-Mo	Backside Thinning Mo/Cu, 45°	20/pk

Frontside Thinning, 26.5°

Frontside Thinning, 26.5°, TEM sample grid coupon designed specially for use in the Short-Cut™ tool. The center portion is a standard 3 mm grid into which the sample loaded needle is swaged and cut 26.5°. Available in two versions: One made from pure copper and the other is molybdenum coated copper.



Cat. No.	Description	Qty.
75976-Cu	Frontside Thinning Copper, 26.5°	20/pk
75976-Mo	Frontside Thinning Mo/Cu, 26.5°	20/pk

Backside Thinning, 26.5°

Backside Thinning, 26.5°, TEM sample grid coupon designed specially for use in the Short-Cut™ tool. The center portion is a standard 3 mm grid into which the sample loaded needle is swaged and cut 26.5°. Available in two versions: One made from pure copper and the other is molybdenum coated copper.

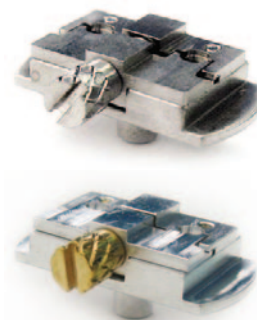


Cat. No.	Description	Qty.
75977-Cu	Backside Thinning Copper, 26.5°	20/pk
75977-Mo	Backside Thinning Mo/Cu, 26.5°	20/pk

Grid & Sample Holders

TEM Grid Dual Holders

Post Base TEM Grid Holder. Available in two versions: stainless steel (SS—very slightly magnetic), can affect imaging in UHS mode; and aluminum (Al-non-magnetic). Short post – standard is 1/8" (3.2mm) diameter x 0.15" (4mm) length.



Cat. No.	Description	Qty.
75968-SS	TEM, Grid Dual Holder, SS	each
75968-Al	TEM, Grid Dual Holder, Al	each

TEM Grid & Sample Holders

TEM grid holder with stations for 2 TEM grids and 2 sample stubs. Available in two versions: stainless steel (SS – very slightly magnetic), and aluminum (Al-non-magnetic). Long post – standard is 1/4" (3.2mm) diameter x 0.32" (8.1mm) length. Comes with 2 sample stubs.



Cat. No.	Description	Qty.
75969-SS	TEM Grid & Sample Holder, SS	each
75969-Al	TEM Grid & Sample Holder, Al	each

Single Stub & Two TEM Grid Holders

This station is meant for 2 TEM grids and 1 sample Pin Stub. Available in Stainless Steel (SS – very slightly magnetic).



Long post – standard is 1/8" (3.2mm) diameter x 0.32" (8.1mm) length. Comes with an aluminum sample stub.

Cat. No.	Description	Qty.
75971-SS	TEM Grid & Sample Holder, SS	each

TEM Grid Holder on a Pin

See page 71.

TEM Grid Freeze Drying Holder

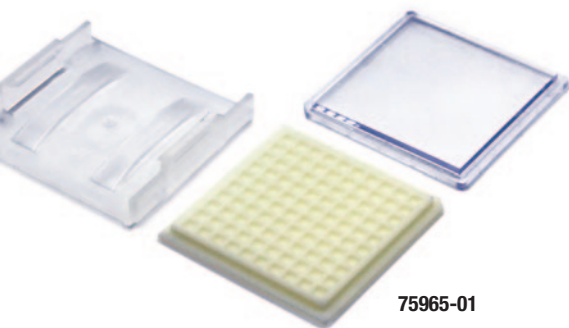
See page 71.

Omni Grid Storage Boxes

Storage box for 100 standard or haft TEM grids—3 mm diameter. Box comes complete with base, lid and clips.

NEW: Anti-Static Omni Grid Storage Box

Same as above but features a black conductive polypropylene tray and anti-static cover, with clip.



Cat. No.	Description	Qty.
75965-01	Omni Grid Storage Box	each
75965-02	Omni Grid Storage Box, Anti-Static	each



LIFT-OUT GRIDS

Omniprobe TEM Grids & Accessories (continued)

III Tungsten/Nickel Probe Tips

Custom tip designed with a nickel tube shank and tungsten tip. Tip radius is 0.5µm with 13° taper angle for maximum lifetime service.



Cat. No.	Description	Qty
75960-01	Tungsten/Nickel Probe Tip	10/bx

III Tungsten Probe Tips

Custom tip designed from tungsten. Tip radius is 0.5µm with 13° taper angle for maximum lifetime service.



Cat. No.	Description	Qty
75960-02	All Tungsten Probe Tip	10/bx

III In-Situ Probe Tips

Custom tungsten tip with a stainless steel shank, for use with AutoProbe™ 300, in-situ probe tip exchange systems and Short-Cut™. Tip radius is 0.5µm with 8–10° taper angle. This tip is also Short-Cut™ compatible.



Cat. No.	Description	Qty
75960-03	in-Situ Probe Tip	20/bx

III Xtreme Access ½" Tungsten Probe Tips

Custom tip designed from tungsten. Tip radius is < 0.5µm with 13° taper angle for maximum lifetime service.



Cat. No.	Description	Qty
75960-04	XA ½" Tungsten Probe Tip	10/bx

III Autoprobe 250 Tungsten Probe Tips

Custom tip designed from tungsten. Tip radius is < 0.5µm with 6° taper angle for maximum lifetime service. Compatible with Short-Cut™ system for direct conversion to TEM grid.



Cat. No.	Description	Qty
75960-05	AP250 Tungsten Probe Tip	10/bx

III Xtreme Access Short-Cut™ Probe Tips

Custom tip designed from tungsten. Tip radius is < 0.5µm with 6° taper angle for maximum lifetime service. Compatible with Short-Cut™ system for direct conversion to TEM grid.



Cat. No.	Description	Qty
75960-06	XA Short Cut Tungsten Probe Tip	10/bx

III XA Probe Point Holder

Xtreme Access Probe Tip Holder for use with ½" tungsten probe tip, #75960-04 and #75960-06.

Comes with a storage vessel.



Cat. No.	Description	Qty
75961-10	XA Probe Point Holder	each

III End Effector Type 3 (Straight)

Straight End Effector for Xtreme Access probe shaft. Available in two versions: Copper (Cu) and Molybdenum (Mo)



Cat. No.	Description	Qty
75981-Cu	Cu Straight End Effector Type 3	12/bx

YOU MAY NEED...

III EMS Tweezer Style SM 110

Straight "T" shaped tips with a vertical groove inside for holding cylindrical objects up to 1mm diameter.

Length: 4-3/4" (120mm).

Absolutely perfect for holding and installing Omniprobe Tips (sold separately). Especially if you're using Cryo-lift out and have to install the tip with the rod already inserted into the SEM chamber.



Forceps provide a firm grip and longitudinal stability reducing the chance of dropping the tip.

Cat. No.	Description	Qty.
78250-100	EMS SM 110 Tweezers	each

Carb-N-Grids™ 2 & 4 Post 3mm Lift-Out Grids

A durable carbon lift-out grid that facilitates precise Elemental Analysis.

Most common lift-out grids are made of copper, nickel, gold and molybdenum, which can all have inherent disadvantages in some scenarios. Carb-N-Grids™ facilitate precise Elemental Analysis by avoiding false peaks that can result from similar materials inside and outside samples. Their unique carbon formula eliminates the need to constantly change grid materials for like samples. In EDS analysis, the difference between the sample and the carbon grid is visible.



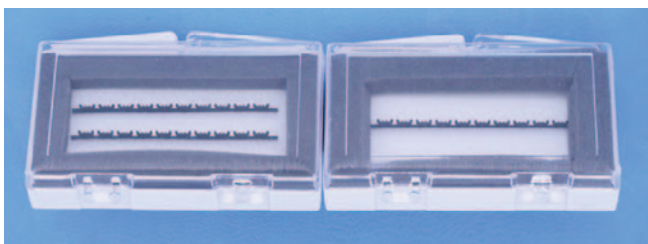
Carb-N-Grids™ with 2 Wide Posts



Carb-N-Grids™ with 2 Wide Posts and 2 Narrow Posts



- For STEM/TEM lamellae milled by FIB or FIB/SEM systems.
- No waste, unlike copper or aluminum grids.
- No false readings due to copper or other trace elements
- No fluorescence
- Secure clamping without bending.
- Available with both post- and V-mounting capability.
- Packaged in a holder with 10 precut grids that break off easily using suitable tweezers.



75966-01



75966-02

Ordering Information

Cat No.	Description	Qty.
75966-01	Carb-N-Grids™ with 2 Wide Posts	10/pk
75966-02	Carb-N-Grids™ with 2 Wide Posts and 2 Narrow Posts	10/pk

Silicon Nitride Lift-Out TEM Windows

Low-stress silicon nitride for lift-out applications

Available with or without gold contacts.

State Of The Art — Our expert engineering and MEMS fabrication processes allow us to provide these one of a kind silicon nitride lift-out grids.

Open Half-Grid Shape — Our Silicon Nitride Lift-Out TEM Windows feature a large, robust window with a freely suspended side along one length of the window, providing an easily accessed edge for sample preparation and thinning to electron transparency (e.g. 50 nm or less).

Ready To Use Gold Contacts — 200 nm thick gold contacts for sample electrical biasing or heating are formatted for FIB-based sample preparation methods.

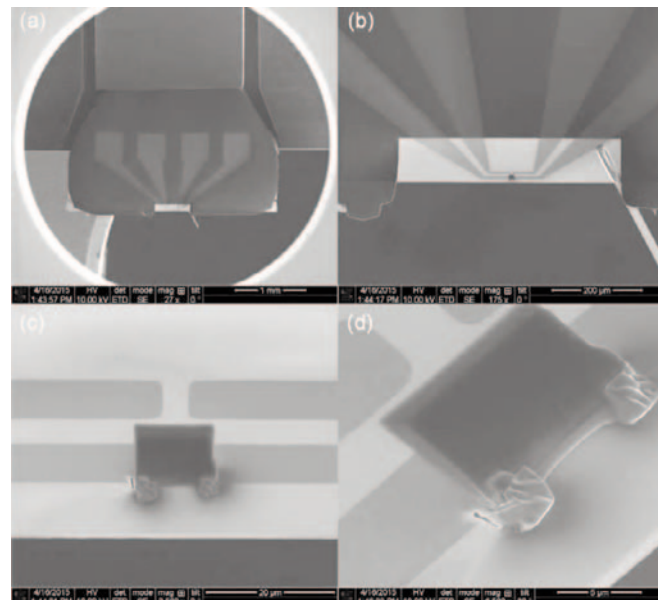
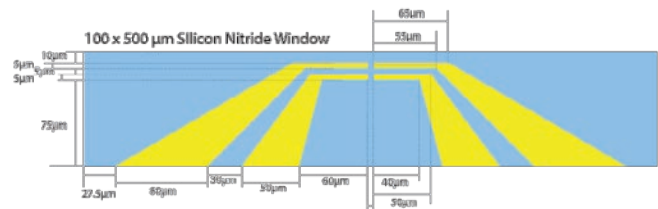


76043-02



76043-01

Schematic of Silicon Nitride Window with Gold Contacts



A view through the electron column down onto the Lift-Out Grid is shown in image (a). In this position the Lift-Out Grid is perpendicular to its edge-on position relative to the electron beam column used to attach the lamella. A higher magnification image of the lamella and silicon nitride membrane is shown in image (b), and an even higher magnification is shown in image (c). Image (d) shows an angled perspective of the Lift-Out Grid and lamella.

Cat. No.	Description	Pack
76043-01	Silicon Nitride Lift-Out TEM Windows with gold contacts	each
76043-02	Silicon Nitride Lift-Out TEM Windows	each

SUPPORT FILM ON GRIDS

To make your microscopy work easier and to save you a great deal of time we offer a complete line of high-quality coated grids. All our coated grids are optically checked followed by batch testing in the EM. They are packed in grid storage boxes.

All the grids below (except the Beryllium Support Films) have the following options:

- Molybdenum grids instead of Au, Cu, Ni
- Silicon-free
- With ultra-thin thickness (thickness can be requested)
- Extra thick thickness

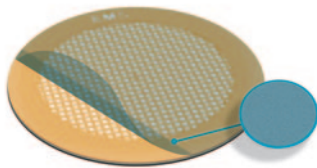
NOTE: All our film is laid on the shiny side of the grid.

Ordering Information Color Code:

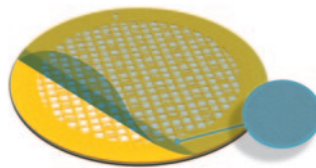


Support Film on Grids Application Guide

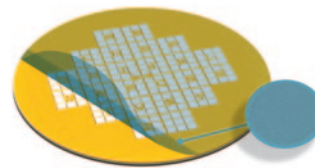
Substrate Application	Formvar Only	Carbon Only	Formvar/Carbon	Formvar/SiO	Silicon SiO	Lacy Film
Diffraction Studies	—	BEST CHOICE	—	GOOD OPTION	GOOD OPTION	SUITABLE
EDS (Energy Dispersive Spectrometry)	—	GOOD OPTION	GOOD OPTION	—	—	SUITABLE
High Resolution Microscopy	—	BEST CHOICE	GOOD OPTION	GOOD OPTION	BEST CHOICE	SUITABLE
High Temp. Techniques/ Heating Stage	—	BEST CHOICE	—	—	GOOD OPTION	SUITABLE
Low Magnification Microscopy	GOOD OPTION	GOOD OPTION	BEST CHOICE	BEST CHOICE	GOOD OPTION	—
Particulate Suspension, Biological	—	BEST CHOICE	GOOD OPTION	BEST CHOICE	BEST CHOICE	SUITABLE
Particulate Suspension, Non-Biological	—	BEST CHOICE	GOOD OPTION	BEST CHOICE	BEST CHOICE	SUITABLE
Powders, Dry	—	GOOD OPTION	GOOD OPTION	BEST CHOICE	GOOD OPTION	—
Replicas, Low Temp. Techniques	GOOD OPTION	GOOD OPTION	BEST CHOICE	—	—	SUITABLE
Suspensions, Bacterial	—	BEST CHOICE	GOOD OPTION	BEST CHOICE	BEST CHOICE	SUITABLE
Suspensions, Cell Fragment	—	BEST CHOICE	BEST CHOICE	BEST CHOICE	BEST CHOICE	SUITABLE
Suspensions, Viral	—	BEST CHOICE	GOOD OPTION	GOOD OPTION	BEST CHOICE	SUITABLE
Thin Sections	GOOD OPTION	GOOD OPTION	BEST CHOICE	GOOD OPTION	BEST CHOICE	SUITABLE



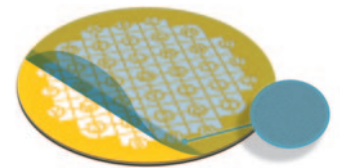
Square Mesh



Gilder Finder Type F1



Gilder Finder Type F2



London Finder

Formvar Film Only

A thin film of pure formvar resin. The thickness range is as follows: **Standard:** Approx. 10nm, **Ultra-Thin (UL):** 5-6nm, **Thick (TH):** 15-20nm, **Extra Thick (ET):** 25-50nm

Formvar Square Mesh

Standard Thickness

Cat. #	Type	Thickness	Qty
FF100-Cu-25	100 MESH	standard	25/box
FF100-Cu-50			50/box
FF150-Cu-25	150 MESH	standard	25/box
FF150-Cu-50			50/box
FF200-Cu-25	200 MESH	standard	25/box
FF200-Cu-50			50/box
FF300-Cu-25	300 MESH	standard	25/box
FF300-Cu-50			50/box
FF400-Cu-25	400 MESH	standard	25/box
FF400-Cu-50			50/box

Cat. #	Type	Thickness	Qty
FF100-Ni-25	100 MESH	standard	25/box
FF100-Ni-50			50/box
FF150-Ni-25	150 MESH	standard	25/box
FF150-Ni-50			50/box
FF200-Ni-25	200 MESH	standard	25/box
FF200-Ni-50			50/box
FF300-Ni-25	300 MESH	standard	25/box
FF300-Ni-50			50/box
FF400-Ni-25	400 MESH	standard	25/box
FF400-Ni-50			50/box

Cat. #	Type	Thickness	Qty
FF100-Au-25	100 MESH	standard	25/box
FF100-Au-50			50/box
FF150-Au-25	150 MESH	standard	25/box
FF150-Au-50			50/box
FF200-Au-25	200 MESH	standard	25/box
FF200-Au-50			50/box
FF300-Au-25	300 MESH	standard	25/box
FF300-Au-50			50/box
FF400-Au-25	400 MESH	standard	25/box
FF400-Au-50			50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty
FF100-Cu-UL	100 MESH	ultra-thin	50/box
FF100-Cu-TH		thick	50/box
FF100-Cu-ET		extra thick	50/box
FF150-Cu-UL	150 MESH	ultra-thin	50/box
FF150-Cu-TH		thick	50/box
FF150-Cu-ET		extra thick	50/box
FF200-Cu-UL	200 MESH	ultra-thin	50/box
FF200-Cu-TH		thick	50/box
FF200-Cu-ET		extra thick	50/box
FF300-Cu-UL	300 MESH	ultra-thin	50/box
FF300-Cu-TH		thick	50/box
FF300-Cu-ET		extra thick	50/box
FF400-Cu-UL	400 MESH	ultra-thin	50/box
FF400-Cu-TH		thick	50/box
FF400-Cu-ET		extra thick	50/box

Cat. #	Type	Thickness	Qty
FF100-Ni-UL	100 MESH	ultra-thin	50/box
FF100-Ni-TH		thick	50/box
FF100-Ni-ET		extra thick	50/box
FF150-Ni-UL	150 MESH	ultra-thin	50/box
FF150-Ni-TH		thick	50/box
FF150-Ni-ET		extra thick	50/box
FF200-Ni-UL	200 MESH	ultra-thin	50/box
FF200-Ni-TH		thick	50/box
FF200-Ni-ET		extra thick	50/box
FF300-Ni-UL	300 MESH	ultra-thin	50/box
FF300-Ni-TH		thick	50/box
FF300-Ni-ET		extra thick	50/box
FF400-Ni-UL	400 MESH	ultra-thin	50/box
FF400-Ni-TH		thick	50/box
FF400-Ni-ET		extra thick	50/box

Cat. #	Type	Thickness	Qty
FF100-Au-UL	100 MESH	ultra-thin	50/box
FF100-Au-TH		thick	50/box
FF100-Au-ET		extra thick	50/box
FF150-Au-UL	150 MESH	ultra-thin	50/box
FF150-Au-TH		thick	50/box
FF150-Au-ET		extra thick	50/box
FF200-Au-UL	200 MESH	ultra-thin	50/box
FF200-Au-TH		thick	50/box
FF200-Au-ET		extra thick	50/box
FF300-Au-UL	300 MESH	ultra-thin	50/box
FF300-Au-TH		thick	50/box
FF300-Au-ET		extra thick	50/box
FF400-Au-UL	400 MESH	ultra-thin	50/box
FF400-Au-TH		thick	50/box
FF400-Au-ET		extra thick	50/box

SUPPORT FILM ON GRIDS

III Formvar Gilder Finder Grids

Standard Thickness

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FF200F1-Cu-25	F1	standard	25/box	FF200F1-Ni-25	F1	standard	25/box	FF200F1-Au-25	F1	standard	25/box
FF200F1-Cu-50			50/box	FF200F1-Ni-50			50/box	FF200F1-Au-50			50/box
FF200F2-Cu-25	F2	standard	25/box	FF200F2-Ni-25	F2	standard	25/box	FF200F2-Au-25	F2	standard	25/box
FF200F2-Cu-50			50/box	FF200F2-Ni-50			50/box	FF200F2-Au-50			50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FF200F1-Cu-UL	F1	thick	50/box	FF200F1-Ni-UL	F1	thick	50/box	FF200F1-Au-UL	F1	thick	50/box
FF200F1-Cu-TH			50/box	FF200F1-Ni-TH			50/box	FF200F1-Au-TH			50/box
FF200F1-Cu-ET			50/box	FF200F1-Ni-ET			50/box	FF200F1-Au-ET			50/box
FF200F2-Cu-UL	F2	thick	50/box	FF200F2-Ni-UL	F2	thick	50/box	FF200F2-Au-UL	F2	thick	50/box
FF200F2-Cu-TH			50/box	FF200F2-Ni-TH			50/box	FF200F2-Au-TH			50/box
FF200F2-Cu-ET			50/box	FF200F2-Ni-ET			50/box	FF200F2-Au-ET			50/box

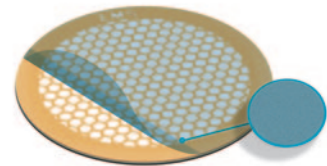
III Formvar London Finder Grids

Standard Thickness

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FFLF135-Cu-25	LF135	standard	25/box	FFLF135-Ni-25	LF135	standard	25/box	FFLF135-Au-25	LF135	standard	25/box
FFLF135-Cu-50			50/box	FFLF135-Ni-50			50/box	FFLF135-Au-50			50/box
FFLF200-Cu-25	LF200	standard	25/box	FFLF200-Ni-25	LF200	standard	25/box	FFLF200-Au-25	LF200	standard	25/box
FFLF200-Cu-50			50/box	FFLF200-Ni-50			50/box	FFLF200-Au-50			50/box
FFLF400-Cu-25	LF400	standard	25/box	FFLF400-Ni-25	LF400	standard	25/box	FFLF400-Au-25	LF400	standard	25/box
FFLF400-Cu-50			50/box	FFLF400-Ni-50			50/box	FFLF400-Au-50			50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FFLF135-Cu-UL	LF135	thick	50/box	FFLF135-Ni-UL	LF135	thick	50/box	FFLF135-Au-UL	LF135	thick	50/box
FFLF135-Cu-TH			50/box	FFLF135-Ni-TH			50/box	FFLF135-Au-TH			50/box
FFLF135-Cu-ET			50/box	FFLF135-Ni-ET			50/box	FFLF135-Au-ET			50/box
FFLF200-Cu-UL	LF200	thick	50/box	FFLF200-Ni-UL	LF200	thick	50/box	FFLF200-Au-UL	LF200	thick	50/box
FFLF200-Cu-TH			50/box	FFLF200-Ni-TH			50/box	FFLF200-Au-TH			50/box
FFLF200-Cu-ET			50/box	FFLF200-Ni-ET			50/box	FFLF200-Au-ET			50/box
FFLF400-Cu-UL	LF400	thick	50/box	FFLF400-Ni-UL	LF400	thick	50/box	FFLF400-Au-UL	LF400	thick	50/box
FFLF400-Cu-TH			50/box	FFLF400-Ni-TH			50/box	FFLF400-Au-TH			50/box
FFLF400-Cu-ET			50/box	FFLF400-Ni-ET			50/box	FFLF400-Au-ET			50/box



Hexagonal Mesh

III Formvar Hexagonal Mesh

Standard Thickness

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FF100H-Cu-25	100 MESH	standard	25/box	FF100H-Ni-25	100 MESH	standard	25/box	FF100H-Au-25	100 MESH	standard	25/box
FF100H-Cu-50			50/box	FF100H-Ni-50			50/box	FF100H-Au-50			50/box
FF200H-Cu-25	200 MESH	standard	25/box	FF200H-Ni-25	200 MESH	standard	25/box	FF200H-Au-25	200 MESH	standard	25/box
FF200H-Cu-50			50/box	FF200H-Ni-50			50/box	FF200H-Au-50			50/box
FF300H-Cu-25	300 MESH	standard	25/box	FF300H-Ni-25	300 MESH	standard	25/box	FF300H-Au-25	300 MESH	standard	25/box
FF300H-Cu-50			50/box	FF300H-Ni-50			50/box	FF300H-Au-50			50/box
FF400H-Cu-25	400 MESH	standard	25/box	FF400H-Ni-25	400 MESH	standard	25/box	FF400H-Au-25	400 MESH	standard	25/box
FF400H-Cu-50			50/box	FF400H-Ni-50			50/box	FF400H-Au-50			50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FF100H-Cu-UL	100 MESH	thick	50/box	FF100H-Ni-UL	100 MESH	thick	50/box	FF100H-Au-UL	100 MESH	thick	50/box
FF100H-Cu-TH			50/box	FF100H-Ni-TH			50/box	FF100H-Au-TH			50/box
FF100H-Cu-ET			50/box	FF100H-Ni-ET			50/box	FF100H-Au-ET			50/box
FF200H-Cu-UL	200 MESH	thick	50/box	FF200H-Ni-UL	200 MESH	thick	50/box	FF200H-Au-UL	200 MESH	thick	50/box
FF200H-Cu-TH			50/box	FF200H-Ni-TH			50/box	FF200H-Au-TH			50/box
FF200H-Cu-ET			50/box	FF200H-Ni-ET			50/box	FF200H-Au-ET			50/box
FF300H-Cu-UL	300 MESH	thick	50/box	FF300H-Ni-UL	300 MESH	thick	50/box	FF300H-Au-UL	300 MESH	thick	50/box
FF300H-Cu-TH			50/box	FF300H-Ni-TH			50/box	FF300H-Au-TH			50/box
FF300H-Cu-ET			50/box	FF300H-Ni-ET			50/box	FF300H-Au-ET			50/box
FF400H-Cu-UL	400 MESH	thick	50/box	FF400H-Ni-UL	400 MESH	thick	50/box	FF400H-Au-UL	400 MESH	thick	50/box
FF400H-Cu-TH			50/box	FF400H-Ni-TH			50/box	FF400H-Au-TH			50/box
FF400H-Cu-ET			50/box	FF400H-Ni-ET			50/box	FF400H-Au-ET			50/box

SUPPORT FILM ON GRIDS

Formvar Thin Bar Square Mesh

Standard Thickness

Cat. #	Type	Thickness	Qty
FFT200-Cu-25 FFT200-Cu-50	200 MESH	standard	25/box 50/box
FFT300-Cu-25 FFT300-Cu-50	300 MESH	standard	25/box 50/box
FFT400-Cu-25 FFT400-Cu-50	400 MESH	standard	25/box 50/box
FFT1000-Cu-25 FFT1000-Cu-50	1000 MESH	standard	25/box 50/box

Cat. #	Type	Thickness	Qty
FFT200-Ni-25 FFT200-Ni-50	200 MESH	standard	25/box 50/box
FFT300-Ni-25 FFT300-Ni-50	300 MESH	standard	25/box 50/box
FFT400-Ni-25 FFT400-Ni-50	400 MESH	standard	25/box 50/box
FFT1000-Ni-25 FFT1000-Ni-50	1000 MESH	standard	25/box 50/box

Cat. #	Type	Thickness	Qty
FFT200-Au-25 FFT200H-Au-50	200 MESH	standard	25/box 50/box
FFT300-Au-25 FFT300-Au-50	300 MESH	standard	25/box 50/box
FFT400-Au-25 FFT400-Au-50	400 MESH	standard	25/box 50/box
FFT1000-Au-25 FFT1000-Au-50	1000 MESH	standard	25/box 50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty
FFT200-Cu-UL FFT200-Cu-TH FFT200-Cu-ET	200 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFT300-Cu-UL FFT300-Cu-TH FFT300-Cu-ET	300 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFT400-Cu-UL FFT400-Cu-TH FFT400-Cu-ET	400 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFT1000-Cu-UL FFT1000-Cu-TH FFT1000-Cu-ET	1000 MESH	ultra-thin thick extra thick	50/box 50/box 50/box

Cat. #	Type	Thickness	Qty
FFT200-Ni-UL FFT200-Ni-TH FFT200-Ni-ET	200 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFT300-Ni-UL FFT300-Ni-TH FFT300-Ni-ET	300 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFT400-Ni-UL FFT400-Ni-TH FFT400-Ni-ET	400 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFT1000-Ni-UL FFT1000-Ni-TH FFT1000-Ni-ET	1000 MESH	ultra-thin thick extra thick	50/box 50/box 50/box

Cat. #	Type	Thickness	Qty
FFT200-Au-UL FFT200-Au-TH FFT200-Au-ET	200 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFT300-Au-UL FFT300-Au-TH FFT300-Au-ET	300 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFT400-Au-UL FFT400-Au-TH FFT400-Au-ET	400 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFT1000-Au-UL FFT1000-Au-TH FFT1000-Au-ET	1000 MESH	ultra-thin thick extra thick	50/box 50/box 50/box

Formvar Thin Bar Hexagonal Mesh

Standard Thickness

Cat. #	Type	Thickness	Qty
FFTH200-Cu-25 FFTH200-Cu-50	200 MESH	standard	25/box 50/box
FFTH300-Cu-25 FFTH300-Cu-50	300 MESH	standard	25/box 50/box
FFTH400-Cu-25 FFTH400-Cu-50	400 MESH	standard	25/box 50/box
FFTH600-Cu-25 FFTH600-Cu-50	600 MESH	standard	25/box 50/box

Cat. #	Type	Thickness	Qty
FFTH200-Ni-25 FFTH200-Ni-50	200 MESH	standard	25/box 50/box
FFTH300-Ni-25 FFTH300-Ni-50	300 MESH	standard	25/box 50/box
FFTH400-Ni-25 FFTH400-Ni-50	400 MESH	standard	25/box 50/box
FFTH600-Ni-25 FFTH600-Ni-50	600 MESH	standard	25/box 50/box

Cat. #	Type	Thickness	Qty
FFTH200-Au-25 FFTH200-Au-50	200 MESH	standard	25/box 50/box
FFTH300-Au-25 FFTH300-Au-50	300 MESH	standard	25/box 50/box
FFTH400-Au-25 FFTH400-Au-50	400 MESH	standard	25/box 50/box
FFTH600-Au-25 FFTH600-Au-50	600 MESH	standard	25/box 50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty
FFTH200-Cu-UL FFTH200-Cu-TH FFTH200-Cu-ET	200 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFTH300-Cu-UL FFTH300-Cu-TH FFTH300-Cu-ET	300 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFTH400-Cu-UL FFTH400-Cu-TH FFTH400-Cu-ET	400 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFTH600-Cu-UL FFTH600-Cu-TH FFTH600-Cu-ET	600 MESH	ultra-thin thick extra thick	50/box 50/box 50/box

Cat. #	Type	Thickness	Qty
FFTH200-Ni-UL FFTH200-Ni-TH FFTH200-Ni-ET	200 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFTH300-Ni-UL FFTH300-Ni-TH FFTH300-Ni-ET	300 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFTH400-Ni-UL FFTH400-Ni-TH FFTH400-Ni-ET	400 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFTH600-Ni-UL FFTH600-Ni-TH FFTH600-Ni-ET	600 MESH	ultra-thin thick extra thick	50/box 50/box 50/box

Cat. #	Type	Thickness	Qty
FFTH200-Au-UL FFTH200-Au-TH FFTH200-Au-ET	200 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFTH300-Au-UL FFTH300-Au-TH FFTH300-Au-ET	300 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFTH400-Au-UL FFTH400-Au-TH FFTH400-Au-ET	400 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
FFTH600-Au-UL FFTH600-Au-TH FFTH600-Au-ET	600 MESH	ultra-thin thick extra thick	50/box 50/box 50/box

Formvar Slots

Standard Thickness

Cat. #	Type	Thickness	Qty
FF205-Cu-25 FF205-Cu-50	2 x 0.5mm	standard	25/box 50/box
FF2010-Cu-25 FF2010-Cu-50	2 x 1mm	standard	25/box 50/box

Cat. #	Type	Thickness	Qty
FF205-Ni-25 FF205-Ni-50	2 x 0.5mm	standard	25/box 50/box
FF2010-Ni-25 FF2010-Ni-50	2 x 1mm	standard	25/box 50/box

Cat. #	Type	Thickness	Qty
FF205-Au-25 FF205-Au-50	2 x 0.5mm	standard	25/box 50/box
FF2010-Au-25 FF2010-Au-50	2 x 1mm	standard	25/box 50/box

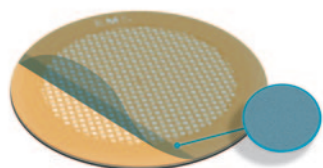
NEW Thickness Ranges

Cat. #	Type	Thickness	Qty
FF205-Cu-UL FF205-Cu-TH FF205-Cu-ET	2 x 0.5mm	ultra-thin thick extra thick	50/box 50/box 50/box
FF2010-Cu-UL FF2010-Cu-TH FF2010-Cu-ET	2 x 1mm	ultra-thin thick extra thick	50/box 50/box 50/box

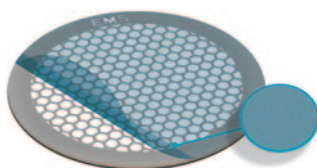
Cat. #	Type	Thickness	Qty
FF205-Ni-UL FF205-Ni-TH FF205-Ni-ET	2 x 0.5mm	ultra-thin thick extra thick	50/box 50/box 50/box
FF2010-Ni-UL FF2010-Ni-TH FF2010-Ni-ET	2 x 1mm	ultra-thin thick extra thick	50/box 50/box 50/box

Cat. #	Type	Thickness	Qty
FF205-Au-UL FF205-Au-TH FF205-Au-ET	2 x 0.5mm	ultra-thin thick extra thick	50/box 50/box 50/box
FF2010-Au-UL FF2010-Au-TH FF2010-Au-ET	2 x 1mm	ultra-thin thick extra thick	50/box 50/box 50/box

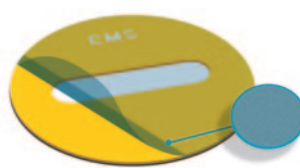
SUPPORT FILM ON GRIDS



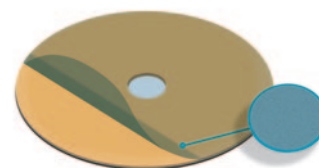
Thin Bar Square Mesh



Thin Bar Hexagonal Mesh



2 x 0.5mm Slot



Single Hole

Formvar Single Hole

Standard Thickness

Cat. #	Type	Thickness	Qty
FFGA75-Cu-25	75 micron	standard	25/box
FFGA75-Cu-50			50/box
FFGA100-Cu-25	100 micron	standard	25/box
FFGA100-Cu-50			50/box
FFGA150-Cu-25	150 micron	standard	25/box
FFGA150-Cu-50			50/box
FFGA200-Cu-25	200 micron	standard	25/box
FFGA200-Cu-50			50/box
FFGA300-Cu-25	300 micron	standard	25/box
FFGA300-Cu-50			50/box
FFGA400-Cu-25	400 micron	standard	25/box
FFGA400-Cu-50			50/box
FFGA600-Cu-25	600 micron	standard	25/box
FFGA600-Cu-50			50/box
FFGA800-Cu-25	800 micron	standard	25/box
FFGA800-Cu-50			50/box
FFGA1000-Cu-25	1000 micron	standard	25/box
FFGA1000-Cu-50			50/box
FFGA1500-Cu-25	1500 micron	standard	25/box
FFGA1500-Cu-50			50/box

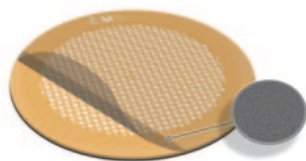
Cat. #	Type	Thickness	Qty
FFGA75-Ni-25	75 micron	standard	25/box
FFGA75-Ni-50			50/box
FFGA100-Ni-25	100 micron	standard	25/box
FFGA100-Ni-50			50/box
FFGA150-Ni-25	150 micron	standard	25/box
FFGA150-Ni-50			50/box
FFGA200-Ni-25	200 micron	standard	25/box
FFGA200-Ni-50			50/box
FFGA300-Ni-25	300 micron	standard	25/box
FFGA300-Ni-50			50/box
FFGA400-Ni-25	400 micron	standard	25/box
FFGA400-Ni-50			50/box
FFGA600-Ni-25	600 micron	standard	25/box
FFGA600-Ni-50			50/box
FFGA800-Ni-25	800 micron	standard	25/box
FFGA800-Ni-50			50/box
FFGA1000-Ni-25	1000 micron	standard	25/box
FFGA1000-Ni-50			50/box
FFGA1500-Ni-25	1500 micron	standard	25/box
FFGA1500-Ni-50			50/box

NEW Thickness Ranges

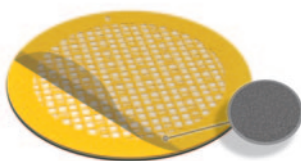
Cat. #	Type	Thickness	Qty
FFGA75-Cu-UL	75 micron	ultra-thin	50/box
FFGA75-Cu-TH		thick	50/box
FFGA75-Cu-ET		extra thick	50/box
FFGA100-Cu-UL	100 micron	ultra-thin	50/box
FFGA100-Cu-TH		thick	50/box
FFGA100-Cu-ET		extra thick	50/box
FFGA150-Cu-UL	150 micron	ultra-thin	50/box
FFGA150-Cu-TH		thick	50/box
FFGA150-Cu-ET		extra thick	50/box
FFGA200-Cu-UL	200 micron	ultra-thin	50/box
FFGA200-Cu-TH		thick	50/box
FFGA200-Cu-ET		extra thick	50/box
FFGA300-Cu-UL	300 micron	ultra-thin	50/box
FFGA300-Cu-TH		thick	50/box
FFGA300-Cu-ET		extra thick	50/box
FFGA400-Cu-UL	400 micron	ultra-thin	50/box
FFGA400-Cu-TH		thick	50/box
FFGA400-Cu-ET		extra thick	50/box
FFGA600-Cu-UL	600 micron	ultra-thin	50/box
FFGA600-Cu-TH		thick	50/box
FFGA600-Cu-ET		extra thick	50/box
FFGA800-Cu-UL	800 micron	ultra-thin	50/box
FFGA800-Cu-TH		thick	50/box
FFGA800-Cu-ET		extra thick	50/box
FFGA1000-Cu-UL	1000 micron	ultra-thin	50/box
FFGA1000-Cu-TH		thick	50/box
FFGA1000-Cu-ET		extra thick	50/box
FFGA1500-Cu-UL	1500 micron	ultra-thin	50/box
FFGA1500-Cu-TH		thick	50/box
FFGA1500-Cu-ET		extra thick	50/box

Cat. #	Type	Thickness	Qty
FFGA75-Ni-UL	75 micron	ultra-thin	50/box
FFGA75-Ni-TH		thick	50/box
FFGA75-Ni-ET		extra thick	50/box
FFGA100-Ni-UL	100 micron	ultra-thin	50/box
FFGA100-Ni-TH		thick	50/box
FFGA100-Ni-ET		extra thick	50/box
FFGA150-Ni-UL	150 micron	ultra-thin	50/box
FFGA150-Ni-TH		thick	50/box
FFGA150-Ni-ET		extra thick	50/box
FFGA200-Ni-UL	200 micron	ultra-thin	50/box
FFGA200-Ni-TH		thick	50/box
FFGA200-Ni-ET		extra thick	50/box
FFGA300-Ni-UL	300 micron	ultra-thin	50/box
FFGA300-Ni-TH		thick	50/box
FFGA300-Ni-ET		extra thick	50/box
FFGA400-Ni-UL	400 micron	ultra-thin	50/box
FFGA400-Ni-TH		thick	50/box
FFGA400-Ni-ET		extra thick	50/box
FFGA600-Ni-UL	600 micron	ultra-thin	50/box
FFGA600-Ni-TH		thick	50/box
FFGA600-Ni-ET		extra thick	50/box
FFGA800-Ni-UL	800 micron	ultra-thin	50/box
FFGA800-Ni-TH		thick	50/box
FFGA800-Ni-ET		extra thick	50/box
FFGA1000-Ni-UL	1000 micron	ultra-thin	50/box
FFGA1000-Ni-TH		thick	50/box
FFGA1000-Ni-ET		extra thick	50/box
FFGA1500-Ni-UL	1500 micron	ultra-thin	50/box
FFGA1500-Ni-TH		thick	50/box
FFGA1500-Ni-ET		extra thick	50/box

SUPPORT FILM ON GRIDS



Square Mesh



Gilder Finder Type F1



Gilder Finder Type F2

Carbon Film Only

A thin film of pure carbon deposited on one side of the grid. The thickness range is as follows: **Standard:** Approx. 5-6nm, **Ultra-Thin (UL):** 3-4nm, **Thick (TH):** 10nm, **Extra Thick (ET):** 20-30nm

Carbon Square Mesh

Standard Thickness

Cat. #	Type	Thickness	Qty
CF150-Cu-25	150 MESH	standard	25/box
CF150-Cu-50		50/box	
CF200-Cu-25	200 MESH	standard	25/box
CF200-Cu-50		50/box	
CF300-Cu-25	300 MESH	standard	25/box
CF300-Cu-50		50/box	
CF400-Cu-25	400 MESH	standard	25/box
CF400-Cu-50		50/box	

Cat. #	Type	Thickness	Qty
CF150-Ni-25	150 MESH	standard	25/box
CF150-Ni-50		50/box	
CF200-Ni-25	200 MESH	standard	25/box
CF200-Ni-50		50/box	
CF300-Ni-25	300 MESH	standard	25/box
CF300-Ni-50		50/box	
CF400-Ni-25	400 MESH	standard	25/box
CF400-Ni-50		50/box	

Cat. #	Type	Thickness	Qty
CF150-Au-25	150 MESH	standard	25/box
CF150-Au-50		50/box	
CF200-Au-25	200 MESH	standard	25/box
CF200-Au-50		50/box	
CF300-Au-25	300 MESH	standard	25/box
CF300-Au-50		50/box	
CF400-Au-25	400 MESH	standard	25/box
CF400-Au-50		50/box	

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty
CF150-Cu-UL	150 MESH	ultra-thin	50/box
CF150-Cu-TH		thick	50/box
CF150-Cu-ET		extra thick	50/box
CF200-Cu-UL	200 MESH	ultra-thin	50/box
CF200-Cu-TH		thick	50/box
CF200-Cu-ET		extra thick	50/box
CF300-Cu-UL	300 MESH	ultra-thin	50/box
CF300-Cu-TH		thick	50/box
CF300-Cu-ET		extra thick	50/box
CF400-Cu-UL	400 MESH	ultra-thin	50/box
CF400-Cu-TH		thick	50/box
CF400-Cu-ET		extra thick	50/box

Cat. #	Type	Thickness	Qty
CF150-Ni-UL	150 MESH	ultra-thin	50/box
CF150-Ni-TH		thick	50/box
CF150-Ni-ET		extra thick	50/box
CF200-Ni-UL	200 MESH	ultra-thin	50/box
CF200-Ni-TH		thick	50/box
CF200-Ni-ET		extra thick	50/box
CF300-Ni-UL	300 MESH	ultra-thin	50/box
CF300-Ni-TH		thick	50/box
CF300-Ni-ET		extra thick	50/box
CF400-Ni-UL	400 MESH	ultra-thin	50/box
CF400-Ni-TH		thick	50/box
CF400-Ni-ET		extra thick	50/box

Cat. #	Type	Thickness	Qty
CF150-Au-UL	150 MESH	ultra-thin	50/box
CF150-Au-TH		thick	50/box
CF150-Au-ET		extra thick	50/box
CF200-Au-UL	200 MESH	ultra-thin	50/box
CF200-Au-TH		thick	50/box
CF200-Au-ET		extra thick	50/box
CF300-Au-UL	300 MESH	ultra-thin	50/box
CF300-Au-TH		thick	50/box
CF300-Au-ET		extra thick	50/box
CF400-Au-UL	400 MESH	ultra-thin	50/box
CF400-Au-TH		thick	50/box
CF400-Au-ET		extra thick	50/box

Carbon Gilder Finder Grids

Standard Thickness

Cat. #	Type	Thickness	Qty
CF200F1-Cu-25	F1	standard	25/box
CF200F1-Cu-50		50/box	
CF200F2-Cu-25	F2	standard	25/box
CF200F2-Cu-50		50/box	

Cat. #	Type	Thickness	Qty
CF200F1-Ni-25	F1	standard	25/box
CF200F1-Ni-50		50/box	
CF200F2-Ni-25	F2	standard	25/box
CF200F2-Ni-50		50/box	

Cat. #	Type	Thickness	Qty
CF200F1-Au-25	F1	standard	25/box
CF200F1-Au-50		50/box	
CF200F2-Au-25	F2	standard	25/box
CF200F2-Au-50		50/box	

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty
CF200F1-Cu-UL	F1	ultra-thin	50/box
CF200F1-Cu-TH		thick	50/box
CF200F1-Cu-ET		extra thick	50/box
CF200F2-Cu-UL	F2	ultra-thin	50/box
CF200F2-Cu-TH		thick	50/box
CF200F2-Cu-ET		extra thick	50/box

Cat. #	Type	Thickness	Qty
CF200F1-Ni-UL	F1	ultra-thin	50/box
CF200F1-Ni-TH		thick	50/box
CF200F1-Ni-ET		extra thick	50/box
CF200F2-Ni-UL	F2	ultra-thin	50/box
CF200F2-Ni-TH		thick	50/box
CF200F2-Ni-ET		extra thick	50/box

Cat. #	Type	Thickness	Qty
CF200F1-Au-UL	F1	ultra-thin	50/box
CF200F1-Au-TH		thick	50/box
CF200F1-Au-ET		extra thick	50/box
CF200F2-Au-UL	F2	ultra-thin	50/box
CF200F2-Au-TH		thick	50/box
CF200F2-Au-ET		extra thick	50/box

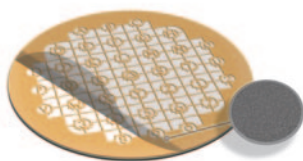
TECHNICAL TIP

Removing a Charge from the Surface of Grids

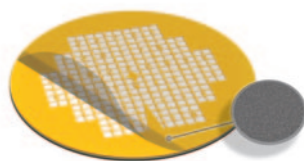
Sometimes when you are trying to pick up sections, they won't adhere to the grid surface. If you don't have time to glow discharge clean the grid surfaces, try this little trick. Dip the grids in distilled water for a moment and wick off the excess with filter paper. Let them dry while you are arranging your sections. Your sections should now adhere to the grid surface. Some labs soak the grids they will use for the day in distilled water until they are needed. If this procedure fails, reclean your grids with acetone or chloroform or glow discharge clean the grid surfaces.

Jeanette Killius, NEOUCOM, Rootstown, OH.

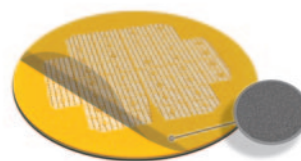
SUPPORT FILM ON GRIDS



London Finder Type LF135



London Finder Type LF200



London Finder Type LF400

III Carbon London Finder Grids

Standard Thickness

Cat. #	Type	Thickness	Qty
CFLF135-Cu-25	LF135	standard	25/box
CFLF135-Cu-50			50/box
CFLF200-Cu-25	LF200	standard	25/box
CFLF200-Cu-50			50/box
CFLF400-Cu-25	LF400	standard	25/box
CFLF400-Cu-50			50/box

Cat. #	Type	Thickness	Qty
CFLF135-Ni-25	LF135	standard	25/box
CFLF135-Ni-50			50/box
CFLF200-Ni-25	LF200	standard	25/box
CFLF200-Ni-50			50/box
CFLF400-Ni-25	LF400	standard	25/box
CFLF400-Ni-50			50/box

Cat. #	Type	Thickness	Qty
CFLF135-Au-25	LF135	standard	25/box
CFLF135-Au-50			50/box
CFLF200-Au-25	LF200	standard	25/box
CFLF200-Au-50			50/box
CFLF400-Au-25	LF400	standard	25/box
CFLF400-Au-50			50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty
CFLF135-Cu-UL	LF135	ultra-thin	50/box
CFLF135-Cu-TH		thick	50/box
CFLF135-Cu-ET		extra thick	50/box
CFLF200-Cu-UL	LF200	ultra-thin	50/box
CFLF200-Cu-TH		thick	50/box
CFLF200-Cu-ET		extra thick	50/box
CFLF400-Cu-UL	LF400	ultra-thin	50/box
CFLF400-Cu-TH		thick	50/box
CFLF400-Cu-ET		extra thick	50/box

Cat. #	Type	Thickness	Qty
CFLF135-Ni-UL	LF135	ultra-thin	50/box
CFLF135-Ni-TH		thick	50/box
CFLF135-Ni-ET		extra thick	50/box
CFLF200-Ni-UL	LF200	ultra-thin	50/box
CFLF200-Ni-TH		thick	50/box
CFLF200-Ni-ET		extra thick	50/box
CFLF400-Ni-UL	LF400	ultra-thin	50/box
CFLF400-Ni-TH		thick	50/box
CFLF400-Ni-ET		extra thick	50/box

Cat. #	Type	Thickness	Qty
CFLF135-Au-UL	LF135	ultra-thin	50/box
CFLF135-Au-TH		thick	50/box
CFLF135-Au-ET		extra thick	50/box



Hexagonal Mesh

III Carbon Hexagonal Mesh

Standard Thickness

Cat. #	Type	Thickness	Qty
CF100H-Cu-25	100 MESH	standard	25/box
CF100H-Cu-50			50/box
CF200H-Cu-25	200 MESH	standard	25/box
CF200H-Cu-50			50/box
CF300H-Cu-25	300 MESH	standard	25/box
CF300H-Cu-50			50/box
CF400H-Cu-25	400 MESH	standard	25/box
CF400H-Cu-50			50/box

Cat. #	Type	Thickness	Qty
CF100H-Ni-25	100 MESH	standard	25/box
CF100H-Ni-50			50/box
CF200H-Ni-25	200 MESH	standard	25/box
CF200H-Ni-50			50/box
CF300H-Ni-25	300 MESH	standard	25/box
CF300H-Ni-50			50/box
CF400H-Ni-25	400 MESH	standard	25/box
CF400H-Ni-50			50/box

Cat. #	Type	Thickness	Qty
CF100H-Au-25	100 MESH	standard	25/box
CF100H-Au-50			50/box
CF200H-Au-25	200 MESH	standard	25/box
CF200H-Au-50			50/box
CF300H-Au-25	300 MESH	standard	25/box
CF300H-Au-50			50/box
CF400H-Au-25	400 MESH	standard	25/box
CF400H-Au-50			50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty
CF100H-Cu-UL	100 MESH	ultra-thin	50/box
CF100H-Cu-TH		thick	50/box
CF100H-Cu-ET		extra thick	50/box
CF200H-Cu-UL	200 MESH	ultra-thin	50/box
CF200H-Cu-TH		thick	50/box
CF200H-Cu-ET		extra thick	50/box
CF300H-Cu-UL	300 MESH	ultra-thin	50/box
CF300H-Cu-TH		thick	50/box
CF300H-Cu-ET		extra thick	50/box
CF400H-Cu-UL	400 MESH	ultra-thin	50/box
CF400H-Cu-TH		thick	50/box
CF400H-Cu-ET		extra thick	50/box

Cat. #	Type	Thickness	Qty
CF100H-Ni-UL	100 MESH	ultra-thin	50/box
CF100H-Ni-TH		thick	50/box
CF100H-Ni-ET		extra thick	50/box
CF200H-Ni-UL	200 MESH	ultra-thin	50/box
CF200H-Ni-TH		thick	50/box
CF200H-Ni-ET		extra thick	50/box
CF300H-Ni-UL	300 MESH	ultra-thin	50/box
CF300H-Ni-TH		thick	50/box
CF300H-Ni-ET		extra thick	50/box
CF400H-Ni-UL	400 MESH	ultra-thin	50/box
CF400H-Ni-TH		thick	50/box
CF400H-Ni-ET		extra thick	50/box

Cat. #	Type	Thickness	Qty
CF100H-Au-UL	100 MESH	ultra-thin	50/box
CF100H-Au-TH		thick	50/box
CF100H-Au-ET		extra thick	50/box
CF200H-Au-UL	200 MESH	ultra-thin	50/box
CF200H-Au-TH		thick	50/box
CF200H-Au-ET		extra thick	50/box
CF300H-Au-UL	300 MESH	ultra-thin	50/box
CF300H-Au-TH		thick	50/box
CF300H-Au-ET		extra thick	50/box
CF400H-Au-UL	400 MESH	ultra-thin	50/box
CF400H-Au-TH		thick	50/box
CF400H-Au-ET		extra thick	50/box

TECHNICAL TIP

A Simple Method for Handling Grids

A simplified method for handling EM grids is described. This new method not only offers safety and identification of your samples but offers you improved handling, temporary storage, and identification of grids bearing ultrathin sections as well as a novel method for preparing bulk samples.

Gorycki, M.(1992). A Simple Method for Handling Grids. Biotechnic & Histochemistry 67/5, 313-314.

SUPPORT FILM ON GRIDS

Carbon Thin Bar Square Mesh

Standard Thickness

Cat. #	Type	Thickness	Qty
CFT200-Cu-25 CFT200-Cu-50	200 MESH	standard	25/box 50/box
CFT300-Cu-25 CFT300-Cu-50	300 MESH	standard	25/box 50/box
CFT400-Cu-25 CFT400-Cu-50	400 MESH	standard	25/box 50/box
CFT1000-Cu-25 CFT1000-Cu-50	1000 MESH	standard	25/box 50/box

Cat. #	Type	Thickness	Qty
CFT200-Ni-25 CFT200-Ni-50	200 MESH	standard	25/box 50/box
CFT300-Ni-25 CFT300-Ni-50	300 MESH	standard	25/box 50/box
CFT400-Ni-25 CFT400-Ni-50	400 MESH	standard	25/box 50/box
CFT1000-Ni-25 CFT1000-Ni-50	1000 MESH	standard	25/box 50/box

Cat. #	Type	Thickness	Qty
CFT200-Au-25 CFT200-Au-50	200 MESH	standard	25/box 50/box
CFT300-Au-25 CFT300-Au-50	300 MESH	standard	25/box 50/box
CFT400-Au-25 CFT400-Au-50	400 MESH	standard	25/box 50/box
CFT1000-Au-25 CFT1000-Au-50	1000 MESH	standard	25/box 50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty
CFT200-Cu-UL CFT200-Cu-TH CFT200-Cu-ET	200 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFT300-Cu-UL CFT300-Cu-TH CFT300-Cu-ET	300 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFT400-Cu-UL CFT400-Cu-TH CFT400-Cu-ET	400 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFT1000-Cu-UL CFT1000-Cu-TH CFT1000-Cu-ET	1000 MESH	ultra-thin thick extra thick	50/box 50/box 50/box

Cat. #	Type	Thickness	Qty
CFT200-Ni-UL CFT200-Ni-TH CFT200-Ni-ET	200 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFT300-Ni-UL CFT300-Ni-TH CFT300-Ni-ET	300 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFT400-Ni-UL CFT400-Ni-TH CFT400-Ni-ET	400 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFT1000-Ni-UL CFT1000-Ni-TH CFT1000-Ni-ET	1000 MESH	ultra-thin thick extra thick	50/box 50/box 50/box

Cat. #	Type	Thickness	Qty
CFT200-Au-UL CFT200-Au-TH CFT200-Au-ET	200 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFT300-Au-UL CFT300-Au-TH CFT300-Au-ET	300 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFT400-Au-UL CFT400-Au-TH CFT400-Au-ET	400 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFT1000-Au-UL CFT1000-Au-TH CFT1000-Au-ET	1000 MESH	ultra-thin thick extra thick	50/box 50/box 50/box

Carbon Thin Bar Hexagonal Mesh

Standard Thickness

Cat. #	Type	Thickness	Qty
CFTH200-Cu-25 CFTH200-Cu-50	200 MESH	standard	25/box 50/box
CFTH300-Cu-25 CFTH300-Cu-50	300 MESH	standard	25/box 50/box
CFTH400-Cu-25 CFTH400-Cu-50	400 MESH	standard	25/box 50/box
CFTH600-Cu-25 CFTH600-Cu-50	600 MESH	standard	25/box 50/box

Cat. #	Type	Thickness	Qty
CFTH200-Ni-25 CFTH200-Ni-50	200 MESH	standard	25/box 50/box
CFTH300-Ni-25 CFTH300-Ni-50	300 MESH	standard	25/box 50/box
CFTH400-Ni-25 CFTH400-Ni-50	400 MESH	standard	25/box 50/box
CFTH600-Ni-25 CFTH600-Ni-50	600 MESH	standard	25/box 50/box

Cat. #	Type	Thickness	Qty
CFTH200-Au-25 CFTH200-Au-50	200 MESH	standard	25/box 50/box
CFTH300-Au-25 CFTH300-Au-50	300 MESH	standard	25/box 50/box
CFTH400-Au-25 CFTH400-Au-50	400 MESH	standard	25/box 50/box
CFTH600-Au-25 CFTH600-Au-50	600 MESH	standard	25/box 50/box

COPPER NICKEL GOLD

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty
CFTH200-Cu-UL CFTH200-Cu-TH CFTH200-Cu-ET	200 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFTH300-Cu-UL CFTH300-Cu-TH CFTH300-Cu-ET	300 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFTH400-Cu-UL CFTH400-Cu-TH CFTH400-Cu-ET	400 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFTH600-Cu-UL CFTH600-Cu-TH CFTH600-Cu-ET	600 MESH	ultra-thin thick extra thick	50/box 50/box 50/box

Cat. #	Type	Thickness	Qty
CFTH200-Ni-UL CFTH200-Ni-TH CFTH200-Ni-ET	200 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFTH300-Ni-UL CFTH300-Ni-TH CFTH300-Ni-ET	300 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFTH400-Ni-UL CFTH400-Ni-TH CFTH400-Ni-ET	400 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFTH600-Ni-UL CFTH600-Ni-TH CFTH600-Ni-ET	600 MESH	ultra-thin thick extra thick	50/box 50/box 50/box

Cat. #	Type	Thickness	Qty
CFTH200-Au-UL CFTH200-Au-TH CFTH200-Au-ET	200 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFTH300-Au-UL CFTH300-Au-TH CFTH300-Au-ET	300 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFTH400-Au-UL CFTH400-Au-TH CFTH400-Au-ET	400 MESH	ultra-thin thick extra thick	50/box 50/box 50/box
CFTH600-Au-UL CFTH600-Au-TH CFTH600-Au-ET	600 MESH	ultra-thin thick extra thick	50/box 50/box 50/box

Carbon Slots

Standard Thickness

Cat. #	Type	Thickness	Qty
CF205-Cu-25 CF205-Cu-50	2 x 0.5mm	standard	25/box 50/box
CF2010-Cu-25 CF2010-Cu-50	2 x 1mm	standard	25/box 50/box

Cat. #	Type	Thickness	Qty
CF205-Ni-25 CF205-Ni-50	2 x 0.5mm	standard	25/box 50/box
CF2010-Ni-25 CF2010-Ni-50	2 x 1mm	standard	25/box 50/box

Cat. #	Type	Thickness	Qty
CF205-Au-25 CF205-Au-50	2 x 0.5mm	standard	25/box 50/box
CF2010-Au-25 CF2010-Au-50	2 x 1mm	standard	25/box 50/box

COPPER NICKEL GOLD

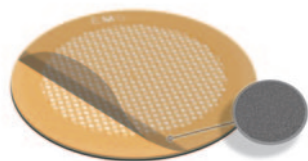
NEW Thickness Ranges

Cat. #	Type	Thickness	Qty
CFT205-Cu-UL CFT205-Cu-TH CFT205-Cu-ET	2 x 0.5mm	ultra-thin thick extra thick	50/box 50/box 50/box
CFT2010-Cu-UL CFT2010-Cu-TH CFT2010-Cu-ET	2 x 1mm	ultra-thin thick extra thick	50/box 50/box 50/box

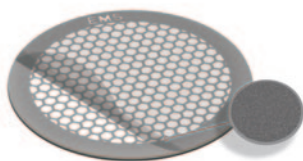
Cat. #	Type	Thickness	Qty
CFT205-Ni-UL CFT205-Ni-TH CFT205-Ni-ET	2 x 0.5mm	ultra-thin thick extra thick	50/box 50/box 50/box
CFT2010-Ni-UL CFT2010-Ni-TH CFT2010-Ni-ET	2 x 1mm	ultra-thin thick extra thick	50/box 50/box 50/box

Cat. #	Type	Thickness	Qty
CFT205-Au-UL CFT205-Au-TH CFT205-Au-ET	2 x 0.5mm	ultra-thin thick extra thick	50/box 50/box 50/box
CFT2010-Au-UL CFT2010-Au-TH CFT2010-Au-ET	2 x 1mm	ultra-thin thick extra thick	50/box 50/box 50/box

SUPPORT FILM ON GRIDS



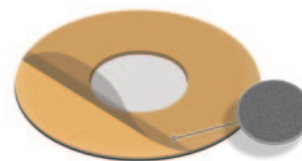
Thin Bar Square Mesh



Thin Bar Hexagonal Mesh



2 x 1 mm Slot



Single Hole

III Carbon Single Hole

Standard Thickness

Cat. #	Type	Thickness	Qty
CFGA75-Cu-25	75 micron	standard	25/box
CFGA75-Cu-50			50/box
CFGA100-Cu-25	100 micron	standard	25/box
CFGA100-Cu-50			50/box
CFGA150-Cu-25	150 micron	standard	25/box
CFGA150-Cu-50			50/box
CFGA200-Cu-25	200 micron	standard	25/box
CFGA200-Cu-50			50/box
CFGA300-Cu-25	300 micron	standard	25/box
CFGA300-Cu-50			50/box
CFGA400-Cu-25	400 micron	standard	25/box
CFGA400-Cu-50			50/box
CFGA600-Cu-25	600 micron	standard	25/box
CFGA600-Cu-50			50/box
CFGA800-Cu-25	800 micron	standard	25/box
CFGA800-Cu-50			50/box
CFGA1000-Cu-25	1000 micron	standard	25/box
CFGA1000-Cu-50			50/box
CFGA1500-Cu-25	1500 micron	standard	25/box
CFGA1500-Cu-50			50/box

Cat. #	Type	Thickness	Qty
CFGA75-Ni-25	75 micron	standard	25/box
CFGA75-Ni-50			50/box
CFGA100-Ni-25	100 micron	standard	25/box
CFGA100-Ni-50			50/box
CFGA150-Ni-25	150 micron	standard	25/box
CFGA150-Ni-50			50/box
CFGA200-Ni-25	200 micron	standard	25/box
CFGA200-Ni-50			50/box
CFGA300-Ni-25	300 micron	standard	25/box
CFGA300-Ni-50			50/box
CFGA400-Ni-25	400 micron	standard	25/box
CFGA400-Ni-50			50/box
CFGA600-Ni-25	600 micron	standard	25/box
CFGA600-Ni-50			50/box
CFGA800-Ni-25	800 micron	standard	25/box
CFGA800-Ni-50			50/box
CFGA1000-Ni-25	1000 micron	standard	25/box
CFGA1000-Ni-50			50/box
CFGA1500-Ni-25	1500 micron	standard	25/box
CFGA1500-Ni-50			50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty
CFGA75-Cu-UL	75 micron	ultra-thin	50/box
CFGA75-Cu-TH		thick	50/box
CFGA75-Cu-ET		extra thick	50/box
CFGA100-Cu-UL	100 micron	ultra-thin	50/box
CFGA100-Cu-TH		thick	50/box
CFGA100-Cu-ET		extra thick	50/box
CFGA150-Cu-UL	150 micron	ultra-thin	50/box
CFGA150-Cu-TH		thick	50/box
CFGA150-Cu-ET		extra thick	50/box
CFGA200-Cu-UL	200 micron	ultra-thin	50/box
CFGA200-Cu-TH		thick	50/box
CFGA200-Cu-ET		extra thick	50/box
CFGA300-Cu-UL	300 micron	ultra-thin	50/box
CFGA300-Cu-TH		thick	50/box
CFGA300-Cu-ET		extra thick	50/box
CFGA400-Cu-UL	400 micron	ultra-thin	50/box
CFGA400-Cu-TH		thick	50/box
CFGA400-Cu-ET		extra thick	50/box
CFGA600-Cu-UL	600 micron	ultra-thin	50/box
CFGA600-Cu-TH		thick	50/box
CFGA600-Cu-ET		extra thick	50/box
CFGA800-Cu-UL	800 micron	ultra-thin	50/box
CFGA800-Cu-TH		thick	50/box
CFGA800-Cu-ET		extra thick	50/box
CFGA1000-Cu-UL	1000 micron	ultra-thin	50/box
CFGA1000-Cu-TH		thick	50/box
CFGA1000-Cu-ET		extra thick	50/box
CFGA1500-Cu-UL	1500 micron	ultra-thin	50/box
CFGA1500-Cu-TH		thick	50/box
CFGA1500-Cu-ET		extra thick	50/box

Cat. #	Type	Thickness	Qty
CFGA75-Ni-UL	75 micron	ultra-thin	50/box
CFGA75-Ni-TH		thick	50/box
CFGA75-Ni-ET		extra thick	50/box
CFGA100-Ni-UL	100 micron	ultra-thin	50/box
CFGA100-Ni-TH		thick	50/box
CFGA100-Ni-ET		extra thick	50/box
CFGA150-Ni-UL	150 micron	ultra-thin	50/box
CFGA150-Ni-TH		thick	50/box
CFGA150-Ni-ET		extra thick	50/box
CFGA200-Ni-UL	200 micron	ultra-thin	50/box
CFGA200-Ni-TH		thick	50/box
CFGA200-Ni-ET		extra thick	50/box
CFGA300-Ni-UL	300 micron	ultra-thin	50/box
CFGA300-Ni-TH		thick	50/box
CFGA300-Ni-ET		extra thick	50/box
CFGA400-Ni-UL	400 micron	ultra-thin	50/box
CFGA400-Ni-TH		thick	50/box
CFGA400-Ni-ET		extra thick	50/box
CFGA600-Ni-UL	600 micron	ultra-thin	50/box
CFGA600-Ni-TH		thick	50/box
CFGA600-Ni-ET		extra thick	50/box
CFGA800-Ni-UL	800 micron	ultra-thin	50/box
CFGA800-Ni-TH		thick	50/box
CFGA800-Ni-ET		extra thick	50/box
CFGA1000-Ni-UL	1000 micron	ultra-thin	50/box
CFGA1000-Ni-TH		thick	50/box
CFGA1000-Ni-ET		extra thick	50/box
CFGA1500-Ni-UL	1500 micron	ultra-thin	50/box
CFGA1500-Ni-TH		thick	50/box
CFGA1500-Ni-ET		extra thick	50/box

SUPPORT FILM ON GRIDS

Formvar/Carbon Film

A formvar coated grid, stabilized with evaporated carbon film. This type of coating is excellent for specimen support, especially for ultra thin sections. The thickness range is as follows:

Standard Option A: 10nm Formvar and 1nm Carbon

Standard Option B (SB): 10nm Formvar and 3-4nm Carbon

Standard Option C (SC): 10nm Formvar and 20-30nm Carbon

Ultra-Thin Option A (UA): 5-6nm Formvar and 1nm Carbon

Ultra-Thin Option B (UB): 5-6nm Formvar and 3-4nm Carbon

Ultra-Thin Option C (UC): 5-6nm Formvar and 20-30nm Carbon

Thick Option A (TA): 15-20nm Formvar and 1nm Carbon

Thick Option B (TB): 15-20nm Formvar and 3-4nm Carbon

Thick Option C (TC): 15-20nm Formvar and 20-30nm Carbon

Extra Thick Option A (EA): 25-50nm Formvar and 1nm Carbon

Extra Thick Option B (EB): 25-50nm Formvar and 3-4nm Carbon

Extra Thick Option C (EC): 25-50nm Formvar and 20-30nm Carbon

Formvar/Carbon Square Mesh

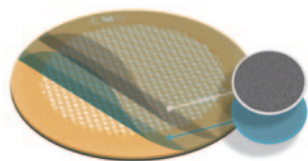
Standard "A" Thickness

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCF100-Cu-25	100 MESH	standard 'A'	25/box	FCF100-Ni-25	100 MESH	standard 'A'	25/box	FCF100-Au-25	100 MESH	standard 'A'	25/box
FCF100-Cu-50			50/box	FCF100-Ni-50			50/box	FCF100-Au-50			50/box
FCF150-Cu-25	150 MESH	standard 'A'	25/box	FCF150-Ni-25	150 MESH	standard 'A'	25/box	FCF150-Au-25	150 MESH	standard 'A'	25/box
FCF150-Cu-50			50/box	FCF150-Ni-50			50/box	FCF150-Au-50			50/box
FCF200-Cu-25	200 MESH	standard 'A'	25/box	FCF200-Ni-25	200 MESH	standard 'A'	25/box	FCF200-Au-25	200 MESH	standard 'A'	25/box
FCF200-Cu-50			50/box	FCF200-Ni-50			50/box	FCF200-Au-50			50/box
FCF300-Cu-25	300 MESH	standard 'A'	25/box	FCF300-Ni-25	300 MESH	standard 'A'	25/box	FCF300-Au-25	300 MESH	standard 'A'	25/box
FCF300-Cu-50			50/box	FCF300-Ni-50			50/box	FCF300-Au-50			50/box
FCF400-Cu-25	400 MESH	standard 'A'	25/box	FCF400-Ni-25	400 MESH	standard 'A'	25/box	FCF400-Au-25	400 MESH	standard 'A'	25/box
FCF400-Cu-50			50/box	FCF400-Ni-50			50/box	FCF400-Au-50			50/box

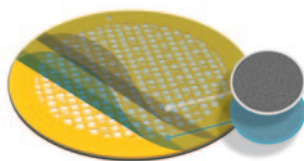
NEW Thickness Ranges

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCF100-Cu-SB	100 MESH	standard 'B'	50/box	FCF100-Ni-SB	100 MESH	standard 'B'	50/box	FCF100-Au-SB	100 MESH	standard 'B'	50/box
FCF100-Cu-SC		standard 'C'	50/box	FCF100-Ni-SC		standard 'C'	50/box	FCF100-Au-SC		standard 'C'	50/box
FCF100-Cu-UA		ultra-thin 'A'	50/box	FCF100-Ni-UA		ultra-thin 'A'	50/box	FCF100-Au-UA		ultra-thin 'A'	50/box
FCF100-Cu-UB		ultra-thin 'B'	50/box	FCF100-Ni-UB		ultra-thin 'B'	50/box	FCF100-Au-UB		ultra-thin 'B'	50/box
FCF100-Cu-UC		ultra-thin 'C'	50/box	FCF100-Ni-UC		ultra-thin 'C'	50/box	FCF100-Au-UC		ultra-thin 'C'	50/box
FCF100-Cu-TA		thick 'A'	50/box	FCF100-Ni-TA		thick 'A'	50/box	FCF100-Au-TA		thick 'A'	50/box
FCF100-Cu-TB		thick 'B'	50/box	FCF100-Ni-TB		thick 'B'	50/box	FCF100-Au-TB		thick 'B'	50/box
FCF100-Cu-TC		thick 'C'	50/box	FCF100-Ni-TC		thick 'C'	50/box	FCF100-Au-TC		thick 'C'	50/box
FCF100-Cu-EA		extra thick 'A'	50/box	FCF100-Ni-EA		extra thick 'A'	50/box	FCF100-Au-EA		extra thick 'A'	50/box
FCF100-Cu-EB		extra thick 'B'	50/box	FCF100-Ni-EB		extra thick 'B'	50/box	FCF100-Au-EB		extra thick 'B'	50/box
FCF100-Cu-EC	extra thick 'C'	50/box	FCF100-Ni-EC	extra thick 'C'	50/box	FCF100-Au-EC	extra thick 'C'	50/box			
FCF150-Cu-SB	150 MESH	standard 'B'	50/box	FCF150-Ni-SB	150 MESH	standard 'B'	50/box	FCF150-Au-SB	150 MESH	standard 'B'	50/box
FCF150-Cu-SC		standard 'C'	50/box	FCF150-Ni-SC		standard 'C'	50/box	FCF150-Au-SC		standard 'C'	50/box
FCF150-Cu-UA		ultra-thin 'A'	50/box	FCF150-Ni-UA		ultra-thin 'A'	50/box	FCF150-Au-UA		ultra-thin 'A'	50/box
FCF150-Cu-UB		ultra-thin 'B'	50/box	FCF150-Ni-UB		ultra-thin 'B'	50/box	FCF150-Au-UB		ultra-thin 'B'	50/box
FCF150-Cu-UC		ultra-thin 'C'	50/box	FCF150-Ni-UC		ultra-thin 'C'	50/box	FCF150-Au-UC		ultra-thin 'C'	50/box
FCF150-Cu-TA		thick 'A'	50/box	FCF150-Ni-TA		thick 'A'	50/box	FCF150-Au-TA		thick 'A'	50/box
FCF150-Cu-TB		thick 'B'	50/box	FCF150-Ni-TB		thick 'B'	50/box	FCF150-Au-TB		thick 'B'	50/box
FCF150-Cu-TC		thick 'C'	50/box	FCF150-Ni-TC		thick 'C'	50/box	FCF150-Au-TC		thick 'C'	50/box
FCF150-Cu-EA		extra thick 'A'	50/box	FCF150-Ni-EA		extra thick 'A'	50/box	FCF150-Au-EA		extra thick 'A'	50/box
FCF150-Cu-EB		extra thick 'B'	50/box	FCF150-Ni-EB		extra thick 'B'	50/box	FCF150-Au-EB		extra thick 'B'	50/box
FCF150-Cu-EC	extra thick 'C'	50/box	FCF150-Ni-EC	extra thick 'C'	50/box	FCF150-Au-EC	extra thick 'C'	50/box			
FCF200-Cu-SB	200 MESH	standard 'B'	50/box	FCF200-Ni-SB	200 MESH	standard 'B'	50/box	FCF200-Au-SB	200 MESH	standard 'B'	50/box
FCF200-Cu-SC		standard 'C'	50/box	FCF200-Ni-SC		standard 'C'	50/box	FCF200-Au-SC		standard 'C'	50/box
FCF200-Cu-UA		ultra-thin 'A'	50/box	FCF200-Ni-UA		ultra-thin 'A'	50/box	FCF200-Au-UA		ultra-thin 'A'	50/box
FCF200-Cu-UB		ultra-thin 'B'	50/box	FCF200-Ni-UB		ultra-thin 'B'	50/box	FCF200-Au-UB		ultra-thin 'B'	50/box
FCF200-Cu-UC		ultra-thin 'C'	50/box	FCF200-Ni-UC		ultra-thin 'C'	50/box	FCF200-Au-UC		ultra-thin 'C'	50/box
FCF200-Cu-TA		thick 'A'	50/box	FCF200-Ni-TA		thick 'A'	50/box	FCF200-Au-TA		thick 'A'	50/box
FCF200-Cu-TB		thick 'B'	50/box	FCF200-Ni-TB		thick 'B'	50/box	FCF200-Au-TB		thick 'B'	50/box
FCF200-Cu-TC		thick 'C'	50/box	FCF200-Ni-TC		thick 'C'	50/box	FCF200-Au-TC		thick 'C'	50/box
FCF200-Cu-EA		extra thick 'A'	50/box	FCF200-Ni-EA		extra thick 'A'	50/box	FCF200-Au-EA		extra thick 'A'	50/box
FCF200-Cu-EB		extra thick 'B'	50/box	FCF200-Ni-EB		extra thick 'B'	50/box	FCF200-Au-EB		extra thick 'B'	50/box
FCF200-Cu-EC	extra thick 'C'	50/box	FCF200-Ni-EC	extra thick 'C'	50/box	FCF200-Au-EC	extra thick 'C'	50/box			

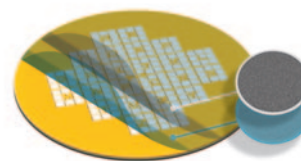
SUPPORT FILM ON GRIDS



Square Mesh



Gilder Finder Type F1



Gilder Finder Type F2

NEW Thickness Ranges (continued)

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCF300-Cu-SB	300 MESH	standard 'B'	50/box	FCF300-Ni-SB	300 MESH	standard 'B'	50/box	FCF300-Au-SB	300 MESH	standard 'B'	50/box
FCF300-Cu-SC		standard 'C'	50/box	FCF300-Ni-SC		standard 'C'	50/box	FCF300-Au-SC		standard 'C'	50/box
FCF300-Cu-UA		ultra-thin 'A'	50/box	FCF300-Ni-UA		ultra-thin 'A'	50/box	FCF300-Au-UA		ultra-thin 'A'	50/box
FCF300-Cu-UB		ultra-thin 'B'	50/box	FCF300-Ni-UB		ultra-thin 'B'	50/box	FCF300-Au-UB		ultra-thin 'B'	50/box
FCF300-Cu-UC		ultra-thin 'C'	50/box	FCF300-Ni-UC		ultra-thin 'C'	50/box	FCF300-Au-UC		ultra-thin 'C'	50/box
FCF300-Cu-TA		thick 'A'	50/box	FCF300-Ni-TA		thick 'A'	50/box	FCF300-Au-TA		thick 'A'	50/box
FCF300-Cu-TB		thick 'B'	50/box	FCF300-Ni-TB		thick 'B'	50/box	FCF300-Au-TB		thick 'B'	50/box
FCF300-Cu-TC		thick 'C'	50/box	FCF300-Ni-TC		thick 'C'	50/box	FCF300-Au-TC		thick 'C'	50/box
FCF300-Cu-EA		extra thick 'A'	50/box	FCF300-Ni-EA		extra thick 'A'	50/box	FCF300-Au-EA		extra thick 'A'	50/box
FCF300-Cu-EB	extra thick 'B'	50/box	FCF300-Ni-EB	extra thick 'B'	50/box	FCF300-Au-EB	extra thick 'B'	50/box			
FCF300-Cu-EC	extra thick 'C'	50/box	FCF300-Ni-EC	extra thick 'C'	50/box	FCF300-Au-EC	extra thick 'C'	50/box			
FCF400-Cu-SB	400 MESH	standard 'B'	50/box	FCF400-Ni-SB	400 MESH	standard 'B'	50/box	FCF400-Au-SB	400 MESH	standard 'B'	50/box
FCF400-Cu-SC		standard 'C'	50/box	FCF400-Ni-SC		standard 'C'	50/box	FCF400-Au-SC		standard 'C'	50/box
FCF400-Cu-UA		ultra-thin 'A'	50/box	FCF400-Ni-UA		ultra-thin 'A'	50/box	FCF400-Au-UA		ultra-thin 'A'	50/box
FCF400-Cu-UB		ultra-thin 'B'	50/box	FCF400-Ni-UB		ultra-thin 'B'	50/box	FCF400-Au-UB		ultra-thin 'B'	50/box
FCF400-Cu-UC		ultra-thin 'C'	50/box	FCF400-Ni-UC		ultra-thin 'C'	50/box	FCF400-Au-UC		ultra-thin 'C'	50/box
FCF400-Cu-TA		thick 'A'	50/box	FCF400-Ni-TA		thick 'A'	50/box	FCF400-Au-TA		thick 'A'	50/box
FCF400-Cu-TB		thick 'B'	50/box	FCF400-Ni-TB		thick 'B'	50/box	FCF400-Au-TB		thick 'B'	50/box
FCF400-Cu-TC		thick 'C'	50/box	FCF400-Ni-TC		thick 'C'	50/box	FCF400-Au-TC		thick 'C'	50/box
FCF400-Cu-EA		extra thick 'A'	50/box	FCF400-Ni-EA		extra thick 'A'	50/box	FCF400-Au-EA		extra thick 'A'	50/box
FCF400-Cu-EB	extra thick 'B'	50/box	FCF400-Ni-EB	extra thick 'B'	50/box	FCF400-Au-EB	extra thick 'B'	50/box			
FCF400-Cu-EC	extra thick 'C'	50/box	FCF400-Ni-EC	extra thick 'C'	50/box	FCF400-Au-EC	extra thick 'C'	50/box			

III Formvar/Carbon Gilder Finder Grids

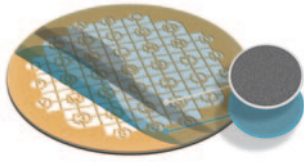
Standard "A" Thickness

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCF200F1-Cu-25	F1	standard 'A'	25/box	FCF200F1-Ni-25	F1	standard 'A'	25/box	FCF200F1-Au-25	F1	standard 'A'	25/box
FCF200F1-Cu-50		standard 'A'	50/box	FCF200F1-Ni-50		standard 'A'	50/box	FCF200F1-Au-50		standard 'A'	50/box
FCF200F2-Cu-25	F2	standard 'A'	25/box	FCF200F2-Ni-25	F2	standard 'A'	25/box	FCF200F2-Au-25	F2	standard 'A'	25/box
FCF200F2-Cu-50		standard 'A'	50/box	FCF200F2-Ni-50		standard 'A'	50/box	FCF200F2-Au-50		standard 'A'	50/box

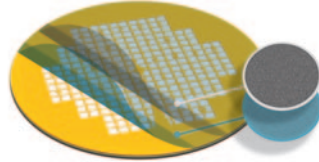
NEW Thickness Ranges

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCF200F1-Cu-SB	F1	standard 'B'	50/box	FCF200F1-Ni-SB	F1	standard 'B'	50/box	FCF200F1-Au-SB	F1	standard 'B'	50/box
FCF200F1-Cu-SC		standard 'C'	50/box	FCF200F1-Ni-SC		standard 'C'	50/box	FCF200F1-Au-SC		standard 'C'	50/box
FCF200F1-Cu-UA		ultra-thin 'A'	50/box	FCF200F1-Ni-UA		ultra-thin 'A'	50/box	FCF200F1-Au-UA		ultra-thin 'A'	50/box
FCF200F1-Cu-UB		ultra-thin 'B'	50/box	FCF200F1-Ni-UB		ultra-thin 'B'	50/box	FCF200F1-Au-UB		ultra-thin 'B'	50/box
FCF200F1-Cu-UC		ultra-thin 'C'	50/box	FCF200F1-Ni-UC		ultra-thin 'C'	50/box	FCF200F1-Au-UC		ultra-thin 'C'	50/box
FCF200F1-Cu-TA		thick 'A'	50/box	FCF200F1-Ni-TA		thick 'A'	50/box	FCF200F1-Au-TA		thick 'A'	50/box
FCF200F1-Cu-TB		thick 'B'	50/box	FCF200F1-Ni-TB		thick 'B'	50/box	FCF200F1-Au-TB		thick 'B'	50/box
FCF200F1-Cu-TC		thick 'C'	50/box	FCF200F1-Ni-TC		thick 'C'	50/box	FCF200F1-Au-TC		thick 'C'	50/box
FCF200F1-Cu-EA		extra thick 'A'	50/box	FCF200F1-Ni-EA		extra thick 'A'	50/box	FCF200F1-Au-EA		extra thick 'A'	50/box
FCF200F1-Cu-EB	extra thick 'B'	50/box	FCF200F1-Ni-EB	extra thick 'B'	50/box	FCF200F1-Au-EB	extra thick 'B'	50/box			
FCF200F1-Cu-EC	extra thick 'C'	50/box	FCF200F1-Ni-EC	extra thick 'C'	50/box	FCF200F1-Au-EC	extra thick 'C'	50/box			
FCF200F2-Cu-SB	F2	standard 'B'	50/box	FCF200F2-Ni-SB	F2	standard 'B'	50/box	FCF200F2-Au-SB	F2	standard 'B'	50/box
FCF200F2-Cu-SC		standard 'C'	50/box	FCF200F2-Ni-SC		standard 'C'	50/box	FCF200F2-Au-SC		standard 'C'	50/box
FCF200F2-Cu-UA		ultra-thin 'A'	50/box	FCF200F2-Ni-UA		ultra-thin 'A'	50/box	FCF200F2-Au-UA		ultra-thin 'A'	50/box
FCF200F2-Cu-UB		ultra-thin 'B'	50/box	FCF200F2-Ni-UB		ultra-thin 'B'	50/box	FCF200F2-Au-UB		ultra-thin 'B'	50/box
FCF200F2-Cu-UC		ultra-thin 'C'	50/box	FCF200F2-Ni-UC		ultra-thin 'C'	50/box	FCF200F2-Au-UC		ultra-thin 'C'	50/box
FCF200F2-Cu-TA		thick 'A'	50/box	FCF200F2-Ni-TA		thick 'A'	50/box	FCF200F2-Au-TA		thick 'A'	50/box
FCF200F2-Cu-TB		thick 'B'	50/box	FCF200F2-Ni-TB		thick 'B'	50/box	FCF200F2-Au-TB		thick 'B'	50/box
FCF200F2-Cu-TC		thick 'C'	50/box	FCF200F2-Ni-TC		thick 'C'	50/box	FCF200F2-Au-TC		thick 'C'	50/box
FCF200F2-Cu-EA		extra thick 'A'	50/box	FCF200F2-Ni-EA		extra thick 'A'	50/box	FCF200F2-Au-EA		extra thick 'A'	50/box
FCF200F2-Cu-EB	extra thick 'B'	50/box	FCF200F2-Ni-EB	extra thick 'B'	50/box	FCF200F2-Au-EB	extra thick 'B'	50/box			
FCF200F2-Cu-EC	extra thick 'C'	50/box	FCF200F2-Ni-EC	extra thick 'C'	50/box	FCF200F2-Au-EC	extra thick 'C'	50/box			

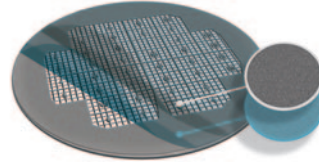
SUPPORT FILM ON GRIDS



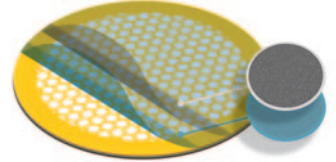
London Finder Type LF135



London Finder Type LF200



London Finder Type LF400



Hexagonal Mesh

Guide to Thickness Ranges

Standard Option A (A): 10nm Formvar and 1nm Carbon

Standard Option B (B): 10nm Formvar and 3-4nm Carbon

Standard Option C (C): 10nm Formvar and 20-30nm Carbon

Ultra-Thin Option A (A): 5-6nm Formvar and 1nm Carbon

Ultra-Thin Option B (B): 5-6nm Formvar and 3-4nm Carbon

Ultra-Thin Option C (C): 5-6nm Formvar and 20-30nm Carbon

Thick Option A (TA): 15-20nm Formvar and 1nm Carbon

Thick Option B (TB): 15-20nm Formvar and 3-4nm Carbon

Thick Option C (TC): 15-20nm Formvar and 20-30nm Carbon

Extra Thick Option A (EA): 25-50nm Formvar and 1nm Carbon

Extra Thick Option B (EB): 25-50nm Formvar and 3-4nm Carbon

Extra Thick Option C (EC): 25-50nm Formvar and 20-30nm Carbon

Formvar/Carbon London Finder Grids

Standard "A" Thickness

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCFLF135-Cu-25	LF135	standard 'A'	25/box	FCFLF135-Ni-25	LF135	standard 'A'	25/box	FCFLF135-Au-25	LF135	standard 'A'	25/box
FCFLF135-Cu-50			50/box	FCFLF135-Ni-50			50/box	FCFLF135-Au-50			50/box
FCFLF200-Cu-25	LF200	standard 'A'	25/box	FCFLF200-Ni-25	LF200	standard 'A'	25/box	FCFLF200-Au-25	LF200	standard 'A'	25/box
FCFLF200-Cu-50			50/box	FCFLF200-Ni-50			50/box	FCFLF200-Au-50			50/box
FCFLF400-Cu-25	LF400	standard 'A'	25/box	FCFLF400-Ni-25	LF400	standard 'A'	25/box	FCFLF400-Au-25	LF400	standard 'A'	25/box
FCFLF400-Cu-50			50/box	FCFLF400-Ni-50			50/box	FCFLF400-Au-50			50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty			
FCFLF135-Cu-SB	LF135	standard 'B'	50/box	FCFLF135-Ni-SB	LF135	standard 'B'	50/box	FCFLF135-Au-SB	LF135	standard 'B'	50/box			
FCFLF135-Cu-SC			standard 'C'	50/box			FCFLF135-Ni-SC	standard 'C'			50/box	FCFLF135-Au-SC	standard 'C'	50/box
FCFLF135-Cu-UA		ultra-thin 'A'	50/box	FCFLF135-Ni-UA		ultra-thin 'A'	50/box	FCFLF135-Au-UA		ultra-thin 'A'	50/box			
FCFLF135-Cu-UB		ultra-thin 'B'	50/box	FCFLF135-Ni-UB		ultra-thin 'B'	50/box	FCFLF135-Au-UB		ultra-thin 'B'	50/box			
FCFLF135-Cu-UC		ultra-thin 'C'	50/box	FCFLF135-Ni-UC		ultra-thin 'C'	50/box	FCFLF135-Au-UC		ultra-thin 'C'	50/box			
FCFLF135-Cu-TA		thick 'A'	50/box	FCFLF135-Ni-TA		thick 'A'	50/box	FCFLF135-Au-TA		thick 'A'	50/box			
FCFLF135-Cu-TB		thick 'B'	50/box	FCFLF135-Ni-TB		thick 'B'	50/box	FCFLF135-Au-TB		thick 'B'	50/box			
FCFLF135-Cu-TC		thick 'C'	50/box	FCFLF135-Ni-TC		thick 'C'	50/box	FCFLF135-Au-TC		thick 'C'	50/box			
FCFLF135-Cu-EA		extra thick 'A'	50/box	FCFLF135-Ni-EA		extra thick 'A'	50/box	FCFLF135-Au-EA		extra thick 'A'	50/box			
FCFLF135-Cu-EB		extra thick 'B'	50/box	FCFLF135-Ni-EB		extra thick 'B'	50/box	FCFLF135-Au-EB		extra thick 'B'	50/box			
FCFLF135-Cu-EC		extra thick 'C'	50/box	FCFLF135-Ni-EC		extra thick 'C'	50/box	FCFLF135-Au-EC		extra thick 'C'	50/box			
FCFLF200-Cu-SB		LF200	standard 'B'	50/box		FCFLF200-Ni-SB	LF200	standard 'B'		50/box	FCFLF200-Au-SB	LF200	standard 'B'	50/box
FCFLF200-Cu-SC				standard 'C'		50/box				FCFLF200-Ni-SC	standard 'C'			50/box
FCFLF200-Cu-UA	ultra-thin 'A'		50/box	FCFLF200-Ni-UA	ultra-thin 'A'	50/box		FCFLF200-Au-UA	ultra-thin 'A'	50/box				
FCFLF200-Cu-UB	ultra-thin 'B'		50/box	FCFLF200-Ni-UB	ultra-thin 'B'	50/box		FCFLF200-Au-UB	ultra-thin 'B'	50/box				
FCFLF200-Cu-UC	ultra-thin 'C'		50/box	FCFLF200-Ni-UC	ultra-thin 'C'	50/box		FCFLF200-Au-UC	ultra-thin 'C'	50/box				
FCFLF200-Cu-TA	thick 'A'		50/box	FCFLF200-Ni-TA	thick 'A'	50/box		FCFLF200-Au-TA	thick 'A'	50/box				
FCFLF200-Cu-TB	thick 'B'		50/box	FCFLF200-Ni-TB	thick 'B'	50/box		FCFLF200-Au-TB	thick 'B'	50/box				
FCFLF200-Cu-TC	thick 'C'		50/box	FCFLF200-Ni-TC	thick 'C'	50/box		FCFLF200-Au-TC	thick 'C'	50/box				
FCFLF200-Cu-EA	extra thick 'A'		50/box	FCFLF200-Ni-EA	extra thick 'A'	50/box		FCFLF200-Au-EA	extra thick 'A'	50/box				
FCFLF200-Cu-EB	extra thick 'B'		50/box	FCFLF200-Ni-EB	extra thick 'B'	50/box		FCFLF200-Au-EB	extra thick 'B'	50/box				
FCFLF200-Cu-EC	extra thick 'C'		50/box	FCFLF200-Ni-EC	extra thick 'C'	50/box		FCFLF200-Au-EC	extra thick 'C'	50/box				
FCFLF400-Cu-SB	LF400		standard 'B'	50/box	FCFLF400-Ni-SB	LF400		standard 'B'	50/box	FCFLF400-Au-SB	LF400		standard 'B'	50/box
FCFLF400-Cu-SC				standard 'C'	50/box				FCFLF400-Ni-SC	standard 'C'				50/box
FCFLF400-Cu-UA		ultra-thin 'A'	50/box	FCFLF400-Ni-UA	ultra-thin 'A'		50/box	FCFLF400-Au-UA	ultra-thin 'A'	50/box				
FCFLF400-Cu-UB		ultra-thin 'B'	50/box	FCFLF400-Ni-UB	ultra-thin 'B'		50/box	FCFLF400-Au-UB	ultra-thin 'B'	50/box				
FCFLF400-Cu-UC		ultra-thin 'C'	50/box	FCFLF400-Ni-UC	ultra-thin 'C'		50/box	FCFLF400-Au-UC	ultra-thin 'C'	50/box				
FCFLF400-Cu-TA		thick 'A'	50/box	FCFLF400-Ni-TA	thick 'A'		50/box	FCFLF400-Au-TA	thick 'A'	50/box				
FCFLF400-Cu-TB		thick 'B'	50/box	FCFLF400-Ni-TB	thick 'B'		50/box	FCFLF400-Au-TB	thick 'B'	50/box				
FCFLF400-Cu-TC		thick 'C'	50/box	FCFLF400-Ni-TC	thick 'C'		50/box	FCFLF400-Au-TC	thick 'C'	50/box				
FCFLF400-Cu-EA		extra thick 'A'	50/box	FCFLF400-Ni-EA	extra thick 'A'		50/box	FCFLF400-Au-EA	extra thick 'A'	50/box				
FCFLF400-Cu-EB		extra thick 'B'	50/box	FCFLF400-Ni-EB	extra thick 'B'		50/box	FCFLF400-Au-EB	extra thick 'B'	50/box				
FCFLF400-Cu-EC		extra thick 'C'	50/box	FCFLF400-Ni-EC	extra thick 'C'		50/box	FCFLF400-Au-EC	extra thick 'C'	50/box				

III Formvar/Carbon Hexagonal Mesh

Standard "A" Thickness

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCF100H-Cu-25	100 MESH	standard 'A'	25/box	FCF100H-Ni-25	100 MESH	standard 'A'	25/box	FCF100H-Au-25	100 MESH	standard 'A'	25/box
FCF100H-Cu-50			50/box	FCF100H-Ni-50			50/box	FCF100H-Au-50			50/box
FCF200H-Cu-25	200 MESH	standard 'A'	25/box	FCF200H-Ni-25	200 MESH	standard 'A'	25/box	FCF200H-Au-25	200 MESH	standard 'A'	25/box
FCF200H-Cu-50			50/box	FCF200H-Ni-50			50/box	FCF200H-Au-50			50/box
FCF300H-Cu-25	300 MESH	standard 'A'	25/box	FCF300H-Ni-25	300 MESH	standard 'A'	25/box	FCF300H-Au-25	300 MESH	standard 'A'	25/box
FCF300H-Cu-50			50/box	FCF300H-Ni-50			50/box	FCF300H-Au-50			50/box
FCF400H-Cu-25	400 MESH	standard 'A'	25/box	FCF400H-Ni-25	400 MESH	standard 'A'	25/box	FCF400H-Au-25	400 MESH	standard 'A'	25/box
FCF400H-Cu-50			50/box	FCF400H-Ni-50			50/box	FCF400H-Au-50			50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty			
FCF100H-Cu-SB	100 MESH	standard 'B'	50/box	FCF100H-Ni-SB	100 MESH	standard 'B'	50/box	FCF100H-Au-SB	100 MESH	standard 'B'	50/box			
FCF100H-Cu-SC			standard 'C'	50/box			FCF100H-Ni-SC	standard 'C'			50/box	FCF100H-Au-SC	standard 'C'	50/box
FCF100H-Cu-UA			ultra-thin 'A'	50/box			FCF100H-Ni-UA	ultra-thin 'A'			50/box	FCF100H-Au-UA	ultra-thin 'A'	50/box
FCF100H-Cu-UB		ultra-thin 'B'	50/box	FCF100H-Ni-UB		ultra-thin 'B'	50/box	FCF100H-Au-UB		ultra-thin 'B'	50/box			
FCF100H-Cu-UC		ultra-thin 'C'	50/box	FCF100H-Ni-UC		ultra-thin 'C'	50/box	FCF100H-Au-UC		ultra-thin 'C'	50/box			
FCF100H-Cu-TA		thick 'A'	50/box	FCF100H-Ni-TA		thick 'A'	50/box	FCF100H-Au-TA		thick 'A'	50/box			
FCF100H-Cu-TB		thick 'B'	50/box	FCF100H-Ni-TB		thick 'B'	50/box	FCF100H-Au-TB		thick 'B'	50/box			
FCF100H-Cu-TC		thick 'C'	50/box	FCF100H-Ni-TC		thick 'C'	50/box	FCF100H-Au-TC		thick 'C'	50/box			
FCF100H-Cu-EA		extra thick 'A'	50/box	FCF100H-Ni-EA		extra thick 'A'	50/box	FCF100H-Au-EA		extra thick 'A'	50/box			
FCF100H-Cu-EB		extra thick 'B'	50/box	FCF100H-Ni-EB		extra thick 'B'	50/box	FCF100H-Au-EB		extra thick 'B'	50/box			
FCF100H-Cu-EC		extra thick 'C'	50/box	FCF100H-Ni-EC		extra thick 'C'	50/box	FCF100H-Au-EC		extra thick 'C'	50/box			
FCF200H-Cu-SB		200 MESH	standard 'B'	50/box		FCF200H-Ni-SB	200 MESH	standard 'B'		50/box	FCF200H-Au-SB	200 MESH	standard 'B'	50/box
FCF200H-Cu-SC				standard 'C'		50/box				FCF200H-Ni-SC	standard 'C'			50/box
FCF200H-Cu-UA	ultra-thin 'A'			50/box	FCF200H-Ni-UA	ultra-thin 'A'			50/box	FCF200H-Au-UA	ultra-thin 'A'			50/box
FCF200H-Cu-UB	ultra-thin 'B'		50/box	FCF200H-Ni-UB	ultra-thin 'B'	50/box		FCF200H-Au-UB	ultra-thin 'B'	50/box				
FCF200H-Cu-UC	ultra-thin 'C'		50/box	FCF200H-Ni-UC	ultra-thin 'C'	50/box		FCF200H-Au-UC	ultra-thin 'C'	50/box				
FCF200H-Cu-TA	thick 'A'		50/box	FCF200H-Ni-TA	thick 'A'	50/box		FCF200H-Au-TA	thick 'A'	50/box				
FCF200H-Cu-TB	thick 'B'		50/box	FCF200H-Ni-TB	thick 'B'	50/box		FCF200H-Au-TB	thick 'B'	50/box				
FCF200H-Cu-TC	thick 'C'		50/box	FCF200H-Ni-TC	thick 'C'	50/box		FCF200H-Au-TC	thick 'C'	50/box				
FCF200H-Cu-EA	extra thick 'A'		50/box	FCF200H-Ni-EA	extra thick 'A'	50/box		FCF200H-Au-EA	extra thick 'A'	50/box				
FCF200H-Cu-EB	extra thick 'B'		50/box	FCF200H-Ni-EB	extra thick 'B'	50/box		FCF200H-Au-EB	extra thick 'B'	50/box				
FCF200H-Cu-EC	extra thick 'C'		50/box	FCF200H-Ni-EC	extra thick 'C'	50/box		FCF200H-Au-EC	extra thick 'C'	50/box				
FCF300H-Cu-SB	300 MESH		standard 'B'	50/box	FCF300H-Ni-SB	300 MESH		standard 'B'	50/box	FCF300H-Au-SB	300 MESH		standard 'B'	50/box
FCF300H-Cu-SC				standard 'C'	50/box				FCF300H-Ni-SC	standard 'C'				50/box
FCF300H-Cu-UA		ultra-thin 'A'		50/box	FCF300H-Ni-UA		ultra-thin 'A'		50/box	FCF300H-Au-UA		ultra-thin 'A'		50/box
FCF300H-Cu-UB		ultra-thin 'B'	50/box	FCF300H-Ni-UB	ultra-thin 'B'		50/box	FCF300H-Au-UB	ultra-thin 'B'	50/box				
FCF300H-Cu-UC		ultra-thin 'C'	50/box	FCF300H-Ni-UC	ultra-thin 'C'		50/box	FCF300H-Au-UC	ultra-thin 'C'	50/box				
FCF300H-Cu-TA		thick 'A'	50/box	FCF300H-Ni-TA	thick 'A'		50/box	FCF300H-Au-TA	thick 'A'	50/box				
FCF300H-Cu-TB		thick 'B'	50/box	FCF300H-Ni-TB	thick 'B'		50/box	FCF300H-Au-TB	thick 'B'	50/box				
FCF300H-Cu-TC		thick 'C'	50/box	FCF300H-Ni-TC	thick 'C'		50/box	FCF300H-Au-TC	thick 'C'	50/box				
FCF300H-Cu-EA		extra thick 'A'	50/box	FCF300H-Ni-EA	extra thick 'A'		50/box	FCF300H-Au-EA	extra thick 'A'	50/box				
FCF300H-Cu-EB		extra thick 'B'	50/box	FCF300H-Ni-EB	extra thick 'B'		50/box	FCF300H-Au-EB	extra thick 'B'	50/box				
FCF300H-Cu-EC		extra thick 'C'	50/box	FCF300H-Ni-EC	extra thick 'C'		50/box	FCF300H-Au-EC	extra thick 'C'	50/box				
FCF400H-Cu-SB		400 MESH	standard 'B'	50/box	FCF400H-Ni-SB		300 MESH	standard 'B'	50/box	FCF400H-Au-SB		400 MESH	standard 'B'	50/box
FCF400H-Cu-SC				standard 'C'	50/box				FCF400H-Ni-SC	standard 'C'				50/box
FCF400H-Cu-UA	ultra-thin 'A'			50/box	FCF400H-Ni-UA	ultra-thin 'A'			50/box	FCF400H-Au-UA	ultra-thin 'A'			50/box
FCF400H-Cu-UB	ultra-thin 'B'		50/box	FCF400H-Ni-UB	ultra-thin 'B'	50/box		FCF400H-Au-UB	ultra-thin 'B'	50/box				
FCF400H-Cu-UC	ultra-thin 'C'		50/box	FCF400H-Ni-UC	ultra-thin 'C'	50/box		FCF400H-Au-UC	ultra-thin 'C'	50/box				
FCF400H-Cu-TA	thick 'A'		50/box	FCF400H-Ni-TA	thick 'A'	50/box		FCF400H-Au-TA	thick 'A'	50/box				
FCF400H-Cu-TB	thick 'B'		50/box	FCF400H-Ni-TB	thick 'B'	50/box		FCF400H-Au-TB	thick 'B'	50/box				
FCF400H-Cu-TC	thick 'C'		50/box	FCF400H-Ni-TC	thick 'C'	50/box		FCF400H-Au-TC	thick 'C'	50/box				
FCF400H-Cu-EA	extra thick 'A'		50/box	FCF400H-Ni-EA	extra thick 'A'	50/box		FCF400H-Au-EA	extra thick 'A'	50/box				
FCF400H-Cu-EB	extra thick 'B'		50/box	FCF400H-Ni-EB	extra thick 'B'	50/box		FCF400H-Au-EB	extra thick 'B'	50/box				
FCF400H-Cu-EC	extra thick 'C'		50/box	FCF400H-Ni-EC	extra thick 'C'	50/box		FCF400H-Au-EC	extra thick 'C'	50/box				

SUPPORT FILM ON GRIDS

Formvar/Carbon Thin Bar Square Mesh

Standard "A" Thickness

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCFT200-Cu-25	200 MESH	standard 'A'	25/box	FCFT200-Ni-25	200 MESH	standard 'A'	25/box	FCFT200-Au-25	200 MESH	standard 'A'	25/box
FCFT200-Cu-50			50/box	FCFT200-Ni-50			50/box	FCFT200-Au-50			50/box
FCFT300-Cu-25	300 MESH	standard 'A'	25/box	FCFT300-Ni-25	300 MESH	standard 'A'	25/box	FCFT300-Au-25	300 MESH	standard 'A'	25/box
FCFT300-Cu-50			50/box	FCFT300-Ni-50			50/box	FCFT300-Au-50			50/box
FCFT400-Cu-25	400 MESH	standard 'A'	25/box	FCFT400-Ni-25	400 MESH	standard 'A'	25/box	FCFT400-Au-25	400 MESH	standard 'A'	25/box
FCFT400-Cu-50			50/box	FCFT400-Ni-50			50/box	FCFT400-Au-50			50/box
FCFT1000-Cu-25	1000 MESH	standard 'A'	25/box	FCFT1000-Ni-25	1000 MESH	standard 'A'	25/box	FCFT1000-Au-25	1000 MESH	standard 'A'	25/box
FCFT1000-Cu-50			50/box	FCFT1000-Ni-50			50/box	FCFT1000-Au-50			50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty			
FCFT200-Cu-SB	200 MESH	standard 'B'	50/box	FCFT200-Ni-SB	200 MESH	standard 'B'	50/box	FCFT200-Au-SB	200 MESH	standard 'B'	50/box			
FCFT200-Cu-SC		standard 'C'	50/box	FCFT200-Ni-SC		standard 'C'	50/box	FCFT200-Au-SC		standard 'C'	50/box			
FCFT200-Cu-UA		ultra-thin 'A'	50/box	FCFT200-Ni-UA		ultra-thin 'A'	50/box	FCFT200-Au-UA		ultra-thin 'A'	50/box			
FCFT200-Cu-UB		ultra-thin 'B'	50/box	FCFT200-Ni-UB		ultra-thin 'B'	50/box	FCFT200-Au-UB		ultra-thin 'B'	50/box			
FCFT200-Cu-UC		ultra-thin 'C'	50/box	FCFT200-Ni-UC		ultra-thin 'C'	50/box	FCFT200-Au-UC		ultra-thin 'C'	50/box			
FCFT200-Cu-TA		thick 'A'	50/box	FCFT200-Ni-TA		thick 'A'	50/box	FCFT200-Au-TA		thick 'A'	50/box			
FCFT200-Cu-TB		thick 'B'	50/box	FCFT200-Ni-TB		thick 'B'	50/box	FCFT200-Au-TB		thick 'B'	50/box			
FCFT200-Cu-TC		thick 'C'	50/box	FCFT200-Ni-TC		thick 'C'	50/box	FCFT200-Au-TC		thick 'C'	50/box			
FCFT200-Cu-EA		extra thick 'A'	50/box	FCFT200-Ni-EA		extra thick 'A'	50/box	FCFT200-Au-EA		extra thick 'A'	50/box			
FCFT200-Cu-EB		extra thick 'B'	50/box	FCFT200-Ni-EB		extra thick 'B'	50/box	FCFT200-Au-EB		extra thick 'B'	50/box			
FCFT200-Cu-EC		extra thick 'C'	50/box	FCFT200-Ni-EC		extra thick 'C'	50/box	FCFT200-Au-EC		extra thick 'C'	50/box			
FCFT300-Cu-SB		300 MESH	standard 'B'	50/box		FCFT300-Ni-SB	300 MESH	standard 'B'		50/box	FCFT300-Au-SB	300 MESH	standard 'B'	50/box
FCFT300-Cu-SC			standard 'C'	50/box		FCFT300-Ni-SC		standard 'C'		50/box	FCFT300-Au-SC		standard 'C'	50/box
FCFT300-Cu-UA	ultra-thin 'A'		50/box	FCFT300-Ni-UA	ultra-thin 'A'	50/box		FCFT300-Au-UA	ultra-thin 'A'	50/box				
FCFT300-Cu-UB	ultra-thin 'B'		50/box	FCFT300-Ni-UB	ultra-thin 'B'	50/box		FCFT300-Au-UB	ultra-thin 'B'	50/box				
FCFT300-Cu-UC	ultra-thin 'C'		50/box	FCFT300-Ni-UC	ultra-thin 'C'	50/box		FCFT300-Au-UC	ultra-thin 'C'	50/box				
FCFT300-Cu-TA	thick 'A'		50/box	FCFT300-Ni-TA	thick 'A'	50/box		FCFT300-Au-TA	thick 'A'	50/box				
FCFT300-Cu-TB	thick 'B'		50/box	FCFT300-Ni-TB	thick 'B'	50/box		FCFT300-Au-TB	thick 'B'	50/box				
FCFT300-Cu-TC	thick 'C'		50/box	FCFT300-Ni-TC	thick 'C'	50/box		FCFT300-Au-TC	thick 'C'	50/box				
FCFT300-Cu-EA	extra thick 'A'		50/box	FCFT300-Ni-EA	extra thick 'A'	50/box		FCFT300-Au-EA	extra thick 'A'	50/box				
FCFT300-Cu-EB	extra thick 'B'		50/box	FCFT300-Ni-EB	extra thick 'B'	50/box		FCFT300-Au-EB	extra thick 'B'	50/box				
FCFT300-Cu-EC	extra thick 'C'		50/box	FCFT300-Ni-EC	extra thick 'C'	50/box		FCFT300-Au-EC	extra thick 'C'	50/box				
FCFT400-Cu-SB	400 MESH		standard 'B'	50/box	FCFT400-Ni-SB	400 MESH		standard 'B'	50/box	FCFT400-Au-SB	400 MESH		standard 'B'	50/box
FCFT400-Cu-SC			standard 'C'	50/box	FCFT400-Ni-SC			standard 'C'	50/box	FCFT400-Au-SC			standard 'C'	50/box
FCFT400-Cu-UA		ultra-thin 'A'	50/box	FCFT400-Ni-UA	ultra-thin 'A'		50/box	FCFT400-Au-UA	ultra-thin 'A'	50/box				
FCFT400-Cu-UB		ultra-thin 'B'	50/box	FCFT400-Ni-UB	ultra-thin 'B'		50/box	FCFT400-Au-UB	ultra-thin 'B'	50/box				
FCFT400-Cu-UC		ultra-thin 'C'	50/box	FCFT400-Ni-UC	ultra-thin 'C'		50/box	FCFT400-Au-UC	ultra-thin 'C'	50/box				
FCFT400-Cu-TA		thick 'A'	50/box	FCFT400-Ni-TA	thick 'A'		50/box	FCFT400-Au-TA	thick 'A'	50/box				
FCFT400-Cu-TB		thick 'B'	50/box	FCFT400-Ni-TB	thick 'B'		50/box	FCFT400-Au-TB	thick 'B'	50/box				
FCFT400-Cu-TC		thick 'C'	50/box	FCFT400-Ni-TC	thick 'C'		50/box	FCFT400-Au-TC	thick 'C'	50/box				
FCFT400-Cu-EA		extra thick 'A'	50/box	FCFT400-Ni-EA	extra thick 'A'		50/box	FCFT400-Au-EA	extra thick 'A'	50/box				
FCFT400-Cu-EB		extra thick 'B'	50/box	FCFT400-Ni-EB	extra thick 'B'		50/box	FCFT400-Au-EB	extra thick 'B'	50/box				
FCFT400-Cu-EC		extra thick 'C'	50/box	FCFT400-Ni-EC	extra thick 'C'		50/box	FCFT400-Au-EC	extra thick 'C'	50/box				
FCFT1000-Cu-SB		1000 MESH	standard 'B'	50/box	FCFT1000-Ni-SB		1000 MESH	standard 'B'	50/box	FCFT1000-Au-SB		1000 MESH	standard 'B'	50/box
FCFT1000-Cu-SC			standard 'C'	50/box	FCFT1000-Ni-SC			standard 'C'	50/box	FCFT1000-Au-SC			standard 'C'	50/box
FCFT1000-Cu-UA	ultra-thin 'A'		50/box	FCFT1000-Ni-UA	ultra-thin 'A'	50/box		FCFT1000-Au-UA	ultra-thin 'A'	50/box				
FCFT1000-Cu-UB	ultra-thin 'B'		50/box	FCFT1000-Ni-UB	ultra-thin 'B'	50/box		FCFT1000-Au-UB	ultra-thin 'B'	50/box				
FCFT1000-Cu-UC	ultra-thin 'C'		50/box	FCFT1000-Ni-UC	ultra-thin 'C'	50/box		FCFT1000-Au-UC	ultra-thin 'C'	50/box				
FCFT1000-Cu-TA	thick 'A'		50/box	FCFT1000-Ni-TA	thick 'A'	50/box		FCFT1000-Au-TA	thick 'A'	50/box				
FCFT1000-Cu-TB	thick 'B'		50/box	FCFT1000-Ni-TB	thick 'B'	50/box		FCFT1000-Au-TB	thick 'B'	50/box				
FCFT1000-Cu-TC	thick 'C'		50/box	FCFT1000-Ni-TC	thick 'C'	50/box		FCFT1000-Au-TC	thick 'C'	50/box				
FCFT1000-Cu-EA	extra thick 'A'		50/box	FCFT1000-Ni-EA	extra thick 'A'	50/box		FCFT1000-Au-EA	extra thick 'A'	50/box				
FCFT1000-Cu-EB	extra thick 'B'		50/box	FCFT1000-Ni-EB	extra thick 'B'	50/box		FCFT1000-Au-EB	extra thick 'B'	50/box				
FCFT1000-Cu-EC	extra thick 'C'		50/box	FCFT1000-Ni-EC	extra thick 'C'	50/box		FCFT1000-Au-EC	extra thick 'C'	50/box				

III Formvar/Carbon Thin Bar Hexagonal Mesh

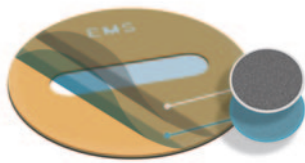
Standard "A" Thickness

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCFTH200-Cu-25	200 MESH	standard 'A'	25/box	FCFTH200-Ni-25	200 MESH	standard 'A'	25/box	FCFTH200-Au-25	200 MESH	standard 'A'	25/box
FCFTH200-Cu-50			50/box	FCFTH200-Ni-50			50/box	FCFTH200-Au-50			50/box
FCFTH300-Cu-25	300 MESH	standard 'A'	25/box	FCFTH300-Ni-25	300 MESH	standard 'A'	25/box	FCFTH300-Au-25	300 MESH	standard 'A'	25/box
FCFTH300-Cu-50			50/box	FCFTH300-Ni-50			50/box	FCFTH300-Au-50			50/box
FCFTH400-Cu-25	400 MESH	standard 'A'	25/box	FCFTH400-Ni-25	400 MESH	standard 'A'	25/box	FCFTH400-Au-25	400 MESH	standard 'A'	25/box
FCFTH400-Cu-50			50/box	FCFTH400-Ni-50			50/box	FCFTH400-Au-50			50/box
FCFTH600-Cu-25	600 MESH	standard 'A'	25/box	FCFTH600-Ni-25	600 MESH	standard 'A'	25/box	FCFTH600-Au-25	600 MESH	standard 'A'	25/box
FCFTH600-Cu-50			50/box	FCFTH600-Ni-50			50/box	FCFTH600-Au-50			50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCFTH200-Cu-SB	200 MESH	standard 'B'	50/box	FCFTH200-Ni-SB	200 MESH	standard 'B'	50/box	FCFTH200-Au-SB	200 MESH	standard 'B'	50/box
FCFTH200-Cu-SC		standard 'C'	50/box	FCFTH200-Ni-SC		standard 'C'	50/box	FCFTH200-Au-SC		standard 'C'	50/box
FCFTH200-Cu-UA		ultra-thin 'A'	50/box	FCFTH200-Ni-UA		ultra-thin 'A'	50/box	FCFTH200-Au-UA		ultra-thin 'A'	50/box
FCFTH200-Cu-UB		ultra-thin 'B'	50/box	FCFTH200-Ni-UB		ultra-thin 'B'	50/box	FCFTH200-Au-UB		ultra-thin 'B'	50/box
FCFTH200-Cu-UC		ultra-thin 'C'	50/box	FCFTH200-Ni-UC		ultra-thin 'C'	50/box	FCFTH200-Au-UC		ultra-thin 'C'	50/box
FCFTH200-Cu-TA		thick 'A'	50/box	FCFTH200-Ni-TA		thick 'A'	50/box	FCFTH200-Au-TA		thick 'A'	50/box
FCFTH200-Cu-TB		thick 'B'	50/box	FCFTH200-Ni-TB		thick 'B'	50/box	FCFTH200-Au-TB		thick 'B'	50/box
FCFTH200-Cu-TC		thick 'C'	50/box	FCFTH200-Ni-TC		thick 'C'	50/box	FCFTH200-Au-TC		thick 'C'	50/box
FCFTH200-Cu-EA		extra thick 'A'	50/box	FCFTH200-Ni-EA		extra thick 'A'	50/box	FCFTH200-Au-EA		extra thick 'A'	50/box
FCFTH200-Cu-EB		extra thick 'B'	50/box	FCFTH200-Ni-EB		extra thick 'B'	50/box	FCFTH200-Au-EB		extra thick 'B'	50/box
FCFTH200-Cu-EC	extra thick 'C'	50/box	FCFTH200-Ni-EC	extra thick 'C'	50/box	FCFTH200-Au-EC	extra thick 'C'	50/box			
FCFTH300-Cu-SB	300 MESH	standard 'B'	50/box	FCFTH300-Ni-SB	300 MESH	standard 'B'	50/box	FCFTH300-Au-SB	300 MESH	standard 'B'	50/box
FCFTH300-Cu-SC		standard 'C'	50/box	FCFTH300-Ni-SC		standard 'C'	50/box	FCFTH300-Au-SC		standard 'C'	50/box
FCFTH300-Cu-UA		ultra-thin 'A'	50/box	FCFTH300-Ni-UA		ultra-thin 'A'	50/box	FCFTH300-Au-UA		ultra-thin 'A'	50/box
FCFTH300-Cu-UB		ultra-thin 'B'	50/box	FCFTH300-Ni-UB		ultra-thin 'B'	50/box	FCFTH300-Au-UB		ultra-thin 'B'	50/box
FCFTH300-Cu-UC		ultra-thin 'C'	50/box	FCFTH300-Ni-UC		ultra-thin 'C'	50/box	FCFTH300-Au-UC		ultra-thin 'C'	50/box
FCFTH300-Cu-TA		thick 'A'	50/box	FCFTH300-Ni-TA		thick 'A'	50/box	FCFTH300-Au-TA		thick 'A'	50/box
FCFTH300-Cu-TB		thick 'B'	50/box	FCFTH300-Ni-TB		thick 'B'	50/box	FCFTH300-Au-TB		thick 'B'	50/box
FCFTH300-Cu-TC		thick 'C'	50/box	FCFTH300-Ni-TC		thick 'C'	50/box	FCFTH300-Au-TC		thick 'C'	50/box
FCFTH300-Cu-EA		extra thick 'A'	50/box	FCFTH300-Ni-EA		extra thick 'A'	50/box	FCFTH300-Au-EA		extra thick 'A'	50/box
FCFTH300-Cu-EB		extra thick 'B'	50/box	FCFTH300-Ni-EB		extra thick 'B'	50/box	FCFTH300-Au-EB		extra thick 'B'	50/box
FCFTH300-Cu-EC	extra thick 'C'	50/box	FCFTH300-Ni-EC	extra thick 'C'	50/box	FCFTH300-Au-EC	extra thick 'C'	50/box			
FCFTH400-Cu-SB	400 MESH	standard 'B'	50/box	FCFTH400-Ni-SB	400 MESH	standard 'B'	50/box	FCFTH400-Au-SB	400 MESH	standard 'B'	50/box
FCFTH400-Cu-SC		standard 'C'	50/box	FCFTH400-Ni-SC		standard 'C'	50/box	FCFTH400-Au-SC		standard 'C'	50/box
FCFTH400-Cu-UA		ultra-thin 'A'	50/box	FCFTH400-Ni-UA		ultra-thin 'A'	50/box	FCFTH400-Au-UA		ultra-thin 'A'	50/box
FCFTH400-Cu-UB		ultra-thin 'B'	50/box	FCFTH400-Ni-UB		ultra-thin 'B'	50/box	FCFTH400-Au-UB		ultra-thin 'B'	50/box
FCFTH400-Cu-UC		ultra-thin 'C'	50/box	FCFTH400-Ni-UC		ultra-thin 'C'	50/box	FCFTH400-Au-UC		ultra-thin 'C'	50/box
FCFTH400-Cu-TA		thick 'A'	50/box	FCFTH400-Ni-TA		thick 'A'	50/box	FCFTH400-Au-TA		thick 'A'	50/box
FCFTH400-Cu-TB		thick 'B'	50/box	FCFTH400-Ni-TB		thick 'B'	50/box	FCFTH400-Au-TB		thick 'B'	50/box
FCFTH400-Cu-TC		thick 'C'	50/box	FCFTH400-Ni-TC		thick 'C'	50/box	FCFTH400-Au-TC		thick 'C'	50/box
FCFTH400-Cu-EA		extra thick 'A'	50/box	FCFTH400-Ni-EA		extra thick 'A'	50/box	FCFTH400-Au-EA		extra thick 'A'	50/box
FCFTH400-Cu-EB		extra thick 'B'	50/box	FCFTH400-Ni-EB		extra thick 'B'	50/box	FCFTH400-Au-EB		extra thick 'B'	50/box
FCFTH400-Cu-EC	extra thick 'C'	50/box	FCFTH400-Ni-EC	extra thick 'C'	50/box	FCFTH400-Au-EC	extra thick 'C'	50/box			
FCFTH600-Cu-SB	600 MESH	standard 'B'	50/box	FCFTH600-Ni-SB	600 MESH	standard 'B'	50/box	FCFTH600-Au-SB	600 MESH	standard 'B'	50/box
FCFTH600-Cu-SC		standard 'C'	50/box	FCFTH600-Ni-SC		standard 'C'	50/box	FCFTH600-Au-SC		standard 'C'	50/box
FCFTH600-Cu-UA		ultra-thin 'A'	50/box	FCFTH600-Ni-UA		ultra-thin 'A'	50/box	FCFTH600-Au-UA		ultra-thin 'A'	50/box
FCFTH600-Cu-UB		ultra-thin 'B'	50/box	FCFTH600-Ni-UB		ultra-thin 'B'	50/box	FCFTH600-Au-UB		ultra-thin 'B'	50/box
FCFTH600-Cu-UC		ultra-thin 'C'	50/box	FCFTH600-Ni-UC		ultra-thin 'C'	50/box	FCFTH600-Au-UC		ultra-thin 'C'	50/box
FCFTH600-Cu-TA		thick 'A'	50/box	FCFTH600-Ni-TA		thick 'A'	50/box	FCFTH600-Au-TA		thick 'A'	50/box
FCFTH600-Cu-TB		thick 'B'	50/box	FCFTH600-Ni-TB		thick 'B'	50/box	FCFTH600-Au-TB		thick 'B'	50/box
FCFTH600-Cu-TC		thick 'C'	50/box	FCFTH600-Ni-TC		thick 'C'	50/box	FCFTH600-Au-TC		thick 'C'	50/box
FCFTH600-Cu-EA		extra thick 'A'	50/box	FCFTH600-Ni-EA		extra thick 'A'	50/box	FCFTH600-Au-EA		extra thick 'A'	50/box
FCFTH600-Cu-EB		extra thick 'B'	50/box	FCFTH600-Ni-EB		extra thick 'B'	50/box	FCFTH600-Au-EB		extra thick 'B'	50/box
FCFTH600-Cu-EC	extra thick 'C'	50/box	FCFTH600-Ni-EC	extra thick 'C'	50/box	FCFTH600-Au-EC	extra thick 'C'	50/box			

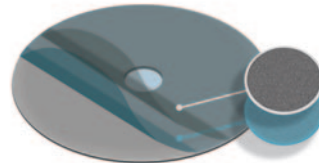
SUPPORT FILM ON GRIDS



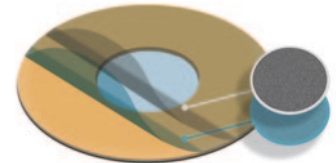
Slot 2 x 0.5mm



Slot 2 x 1mm



Single Hole



Single Hole

Formvar/Carbon Slots

Standard "A" Thickness

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCF205-Cu-25	2 x 0.5mm	standard 'A'	25/box	FCF205-Ni-25	2 x 0.5mm	standard 'A'	25/box	FCF205-Au-25	2 x 0.5mm	standard 'A'	25/box
FCF205-Cu-50			50/box	FCF205-Ni-50			50/box	FCF205-Au-50			50/box
FCF2010-Cu-25	2 x 1mm	standard 'A'	25/box	FCF2010-Ni-25	2 x 1mm	standard 'A'	25/box	FCF2010-Au-25	2 x 1mm	standard 'A'	25/box
FCF2010-Cu-50			50/box	FCF2010-Ni-50			50/box	FCF2010-Au-50			50/box

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty			
FCF205-Cu-SB	2 x 0.5mm	standard 'B'	50/box	FCF205-Ni-SB	2 x 0.5mm	standard 'B'	50/box	FCF205-Au-SB	2 x 0.5mm	standard 'B'	50/box			
FCF205-Cu-SC		standard 'C'	50/box	FCF205-Ni-SC		standard 'C'	50/box	FCF205-Au-SC		standard 'C'	50/box			
FCF205-Cu-UA	2 x 0.5mm	ultra-thin 'A'	50/box	FCF205-Ni-UA	2 x 0.5mm	ultra-thin 'A'	50/box	FCF205-Au-UA	2 x 0.5mm	ultra-thin 'A'	50/box			
FCF205-Cu-UB		ultra-thin 'B'	50/box	FCF205-Ni-UB		ultra-thin 'B'	50/box	FCF205-Au-UB		ultra-thin 'B'	50/box			
FCF205-Cu-UC		ultra-thin 'C'	50/box	FCF205-Ni-UC		ultra-thin 'C'	50/box	FCF205-Au-UC		ultra-thin 'C'	50/box			
FCF205-Cu-TA		thick 'A'	50/box	FCF205-Ni-TA		thick 'A'	50/box	FCF205-Au-TA		thick 'A'	50/box			
FCF205-Cu-TB		thick 'B'	50/box	FCF205-Ni-TB		thick 'B'	50/box	FCF205-Au-TB		thick 'B'	50/box			
FCF205-Cu-TC		thick 'C'	50/box	FCF205-Ni-TC		thick 'C'	50/box	FCF205-Au-TC		thick 'C'	50/box			
FCF205-Cu-EA		extra thick 'A'	50/box	FCF205-Ni-EA		extra thick 'A'	50/box	FCF205-Au-EA		extra thick 'A'	50/box			
FCF205-Cu-EB		extra thick 'B'	50/box	FCF205-Ni-EB		extra thick 'B'	50/box	FCF205-Au-EB		extra thick 'B'	50/box			
FCF205-Cu-EC		extra thick 'C'	50/box	FCF205-Ni-EC		extra thick 'C'	50/box	FCF205-Au-EC		extra thick 'C'	50/box			
FCF2010-Cu-SB		2 x 1mm	standard 'B'	50/box		FCF2010-Ni-SB	2 x 1mm	standard 'B'		50/box	FCF2010-Au-SB	2 x 1mm	standard 'B'	50/box
FCF2010-Cu-SC			standard 'C'	50/box		FCF2010-Ni-SC		standard 'C'		50/box	FCF2010-Au-SC		standard 'C'	50/box
FCF2010-Cu-UA			ultra-thin 'A'	50/box		FCF2010-Ni-UA		ultra-thin 'A'		50/box	FCF2010-Au-UA		ultra-thin 'A'	50/box
FCF2010-Cu-UB	ultra-thin 'B'		50/box	FCF2010-Ni-UB	ultra-thin 'B'	50/box		FCF2010-Au-UB	ultra-thin 'B'	50/box				
FCF2010-Cu-UC	ultra-thin 'C'		50/box	FCF2010-Ni-UC	ultra-thin 'C'	50/box		FCF2010-Au-UC	ultra-thin 'C'	50/box				
FCF2010-Cu-TA	thick 'A'		50/box	FCF2010-Ni-TA	thick 'A'	50/box		FCF2010-Au-TA	thick 'A'	50/box				
FCF2010-Cu-TB	thick 'B'		50/box	FCF2010-Ni-TB	thick 'B'	50/box		FCF2010-Au-TB	thick 'B'	50/box				
FCF2010-Cu-TC	thick 'C'		50/box	FCF2010-Ni-TC	thick 'C'	50/box		FCF2010-Au-TC	thick 'C'	50/box				
FCF2010-Cu-EA	extra thick 'A'		50/box	FCF2010-Ni-EA	extra thick 'A'	50/box		FCF2010-Au-EA	extra thick 'A'	50/box				
FCF2010-Cu-EB	extra thick 'B'		50/box	FCF2010-Ni-EB	extra thick 'B'	50/box		FCF2010-Au-EB	extra thick 'B'	50/box				
FCF2010-Cu-EC	extra thick 'C'		50/box	FCF2010-Ni-EC	extra thick 'C'	50/box		FCF2010-Au-EC	extra thick 'C'	50/box				

Formvar/Carbon Single Hole

Standard "A" Thickness

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCFGA75-Cu-25	75 micron	standard 'A'	25/box	FCFGA75-Ni-25	75 micron	standard 'A'	25/box
FCFGA75-Cu-50			50/box	FCFGA75-Ni-50			50/box
FCFGA100-Cu-25	100 micron	standard 'A'	25/box	FCFGA100-Ni-25	100 micron	standard 'A'	25/box
FCFGA100-Cu-50			50/box	FCFGA100-Ni-50			50/box
FCFGA150-Cu-25	150 micron	standard 'A'	25/box	FCFGA150-Ni-25	150 micron	standard 'A'	25/box
FCFGA150-Cu-50			50/box	FCFGA150-Ni-50			50/box
FCFGA200-Cu-25	200 micron	standard 'A'	25/box	FCFGA200-Ni-25	200 micron	standard 'A'	25/box
FCFGA200-Cu-50			50/box	FCFGA200-Ni-50			50/box
FCFGA300-Cu-25	300 micron	standard 'A'	25/box	FCFGA300-Ni-25	300 micron	standard 'A'	25/box
FCFGA300-Cu-50			50/box	FCFGA300-Ni-50			50/box
FCFGA400-Cu-25	400 micron	standard 'A'	25/box	FCFGA400-Ni-25	400 micron	standard 'A'	25/box
FCFGA400-Cu-50			50/box	FCFGA400-Ni-50			50/box
FCFGA600-Cu-25	600 micron	standard 'A'	25/box	FCFGA600-Ni-25	600 micron	standard 'A'	25/box
FCFGA600-Cu-50			50/box	FCFGA600-Ni-50			50/box
FCFGA800-Cu-25	800 micron	standard 'A'	25/box	FCFGA800-Ni-25	800 micron	standard 'A'	25/box
FCFGA800-Cu-50			50/box	FCFGA800-Ni-50			50/box
FCFGA1000-Cu-25	1000 micron	standard 'A'	25/box	FCFGA1000-Ni-25	1000 micron	standard 'A'	25/box
FCFGA1000-Cu-50			50/box	FCFGA1000-Ni-50			50/box
FCFGA1500-Cu-25	1500 micron	standard 'A'	25/box	FCFGA1500-Ni-25	1500 micron	standard 'A'	25/box
FCFGA1500-Cu-50			50/box	FCFGA1500-Ni-50			50/box

III Formvar/Carbon Single Hole (continued)

NEW Thickness Ranges

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCFGA75-Cu-SB	75 micron	standard 'B'	50/box	FCFGA75-Ni-SB	75 micron	standard 'B'	50/box
FCFGA75-Cu-SC		standard 'C'	50/box	FCFGA75-Ni-SC		standard 'C'	50/box
FCFGA75-Cu-UA		ultra-thin 'A'	50/box	FCFGA75-Ni-UA		ultra-thin 'A'	50/box
FCFGA75-Cu-UB		ultra-thin 'B'	50/box	FCFGA75-Ni-UB		ultra-thin 'B'	50/box
FCFGA75-Cu-UC		ultra-thin 'C'	50/box	FCFGA75-Ni-UC		ultra-thin 'C'	50/box
FCFGA75-Cu-TA		thick 'A'	50/box	FCFGA75-Ni-TA		thick 'A'	50/box
FCFGA75-Cu-TB		thick 'B'	50/box	FCFGA75-Ni-TB		thick 'B'	50/box
FCFGA75-Cu-TC		thick 'C'	50/box	FCFGA75-Ni-TC		thick 'C'	50/box
FCFGA75-Cu-EA		extra thick 'A'	50/box	FCFGA75-Ni-EA		extra thick 'A'	50/box
FCFGA75-Cu-EB		extra thick 'B'	50/box	FCFGA75-Ni-EB		extra thick 'B'	50/box
FCFGA75-Cu-EC		extra thick 'C'	50/box	FCFGA75-Ni-EC		extra thick 'C'	50/box
FCFGA100-Cu-SB		100 micron	standard 'B'	50/box		FCFGA100-Ni-SB	100 micron
FCFGA100-Cu-SC	standard 'C'		50/box	FCFGA100-Ni-SC	standard 'C'	50/box	
FCFGA100-Cu-UA	ultra-thin 'A'		50/box	FCFGA100-Ni-UA	ultra-thin 'A'	50/box	
FCFGA100-Cu-UB	ultra-thin 'B'		50/box	FCFGA100-Ni-UB	ultra-thin 'B'	50/box	
FCFGA100-Cu-UC	ultra-thin 'C'		50/box	FCFGA100-Ni-UC	ultra-thin 'C'	50/box	
FCFGA100-Cu-TA	thick 'A'		50/box	FCFGA100-Ni-TA	thick 'A'	50/box	
FCFGA100-Cu-TB	thick 'B'		50/box	FCFGA100-Ni-TB	thick 'B'	50/box	
FCFGA100-Cu-TC	thick 'C'		50/box	FCFGA100-Ni-TC	thick 'C'	50/box	
FCFGA100-Cu-EA	extra thick 'A'		50/box	FCFGA100-Ni-EA	extra thick 'A'	50/box	
FCFGA100-Cu-EB	extra thick 'B'		50/box	FCFGA100-Ni-EB	extra thick 'B'	50/box	
FCFGA100-Cu-EC	extra thick 'C'		50/box	FCFGA100-Ni-EC	extra thick 'C'	50/box	
FCFGA150-Cu-SB	150 micron		standard 'B'	50/box	FCFGA150-Ni-SB	150 micron	
FCFGA150-Cu-SC		standard 'C'	50/box	FCFGA150-Ni-SC	standard 'C'		50/box
FCFGA150-Cu-UA		ultra-thin 'A'	50/box	FCFGA150-Ni-UA	ultra-thin 'A'		50/box
FCFGA150-Cu-UB		ultra-thin 'B'	50/box	FCFGA150-Ni-UB	ultra-thin 'B'		50/box
FCFGA150-Cu-UC		ultra-thin 'C'	50/box	FCFGA150-Ni-UC	ultra-thin 'C'		50/box
FCFGA150-Cu-TA		thick 'A'	50/box	FCFGA150-Ni-TA	thick 'A'		50/box
FCFGA150-Cu-TB		thick 'B'	50/box	FCFGA150-Ni-TB	thick 'B'		50/box
FCFGA150-Cu-TC		thick 'C'	50/box	FCFGA150-Ni-TC	thick 'C'		50/box
FCFGA150-Cu-EA		extra thick 'A'	50/box	FCFGA150-Ni-EA	extra thick 'A'		50/box
FCFGA150-Cu-EB		extra thick 'B'	50/box	FCFGA150-Ni-EB	extra thick 'B'		50/box
FCFGA150-Cu-EC		extra thick 'C'	50/box	FCFGA150-Ni-EC	extra thick 'C'		50/box
FCFGA200-Cu-SB		200 micron	standard 'B'	50/box	FCFGA200-Ni-SB		200 micron
FCFGA200-Cu-SC	standard 'C'		50/box	FCFGA200-Ni-SC	standard 'C'	50/box	
FCFGA200-Cu-UA	ultra-thin 'A'		50/box	FCFGA200-Ni-UA	ultra-thin 'A'	50/box	
FCFGA200-Cu-UB	ultra-thin 'B'		50/box	FCFGA200-Ni-UB	ultra-thin 'B'	50/box	
FCFGA200-Cu-UC	ultra-thin 'C'		50/box	FCFGA200-Ni-UC	ultra-thin 'C'	50/box	
FCFGA200-Cu-TA	thick 'A'		50/box	FCFGA200-Ni-TA	thick 'A'	50/box	
FCFGA200-Cu-TB	thick 'B'		50/box	FCFGA200-Ni-TB	thick 'B'	50/box	
FCFGA200-Cu-TC	thick 'C'		50/box	FCFGA200-Ni-TC	thick 'C'	50/box	
FCFGA200-Cu-EA	extra thick 'A'		50/box	FCFGA200-Ni-EA	extra thick 'A'	50/box	
FCFGA200-Cu-EB	extra thick 'B'		50/box	FCFGA200-Ni-EB	extra thick 'B'	50/box	
FCFGA200-Cu-EC	extra thick 'C'		50/box	FCFGA200-Ni-EC	extra thick 'C'	50/box	
FCFGA300-Cu-SB	300 micron		standard 'B'	50/box	FCFGA300-Ni-SB	300 micron	
FCFGA300-Cu-SC		standard 'C'	50/box	FCFGA300-Ni-SC	standard 'C'		50/box
FCFGA300-Cu-UA		ultra-thin 'A'	50/box	FCFGA300-Ni-UA	ultra-thin 'A'		50/box
FCFGA300-Cu-UB		ultra-thin 'B'	50/box	FCFGA300-Ni-UB	ultra-thin 'B'		50/box
FCFGA300-Cu-UC		ultra-thin 'C'	50/box	FCFGA300-Ni-UC	ultra-thin 'C'		50/box
FCFGA300-Cu-TA		thick 'A'	50/box	FCFGA300-Ni-TA	thick 'A'		50/box
FCFGA300-Cu-TB		thick 'B'	50/box	FCFGA300-Ni-TB	thick 'B'		50/box
FCFGA300-Cu-TC		thick 'C'	50/box	FCFGA300-Ni-TC	thick 'C'		50/box
FCFGA300-Cu-EA		extra thick 'A'	50/box	FCFGA300-Ni-EA	extra thick 'A'		50/box
FCFGA300-Cu-EB		extra thick 'B'	50/box	FCFGA300-Ni-EB	extra thick 'B'		50/box
FCFGA300-Cu-EC		extra thick 'C'	50/box	FCFGA300-Ni-EC	extra thick 'C'		50/box
FCFGA400-Cu-SB		400 micron	standard 'B'	50/box	FCFGA400-Ni-SB		400 micron
FCFGA400-Cu-SC	standard 'C'		50/box	FCFGA400-Ni-SC	standard 'C'	50/box	
FCFGA400-Cu-UA	ultra-thin 'A'		50/box	FCFGA400-Ni-UA	ultra-thin 'A'	50/box	
FCFGA400-Cu-UB	ultra-thin 'B'		50/box	FCFGA400-Ni-UB	ultra-thin 'B'	50/box	
FCFGA400-Cu-UC	ultra-thin 'C'		50/box	FCFGA400-Ni-UC	ultra-thin 'C'	50/box	
FCFGA400-Cu-TA	thick 'A'		50/box	FCFGA400-Ni-TA	thick 'A'	50/box	
FCFGA400-Cu-TB	thick 'B'		50/box	FCFGA400-Ni-TB	thick 'B'	50/box	
FCFGA400-Cu-TC	thick 'C'		50/box	FCFGA400-Ni-TC	thick 'C'	50/box	
FCFGA400-Cu-EA	extra thick 'A'		50/box	FCFGA400-Ni-EA	extra thick 'A'	50/box	
FCFGA400-Cu-EB	extra thick 'B'		50/box	FCFGA400-Ni-EB	extra thick 'B'	50/box	
FCFGA400-Cu-EC	extra thick 'C'		50/box	FCFGA400-Ni-EC	extra thick 'C'	50/box	

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SUPPORT FILM ON GRIDS

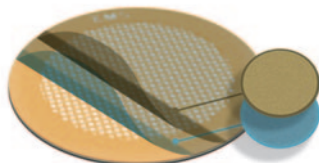
III Formvar/Carbon Single Hole (continued)

NEW Thickness Ranges (continued)

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
FCFGA600-Cu-SB	600 micron	standard 'B'	50/box	FCFGA600-Ni-SB	600 micron	standard 'B'	50/box
FCFGA600-Cu-SC		standard 'C'	50/box	FCFGA600-Ni-SC		standard 'C'	50/box
FCFGA600-Cu-UA		ultra-thin 'A'	50/box	FCFGA600-Ni-UA		ultra-thin 'A'	50/box
FCFGA600-Cu-UB		ultra-thin 'B'	50/box	FCFGA600-Ni-UB		ultra-thin 'B'	50/box
FCFGA600-Cu-UC		ultra-thin 'C'	50/box	FCFGA600-Ni-UC		ultra-thin 'C'	50/box
FCFGA600-Cu-TA		thick 'A'	50/box	FCFGA600-Ni-TA		thick 'A'	50/box
FCFGA600-Cu-TB		thick 'B'	50/box	FCFGA600-Ni-TB		thick 'B'	50/box
FCFGA600-Cu-TC		thick 'C'	50/box	FCFGA600-Ni-TC		thick 'C'	50/box
FCFGA600-Cu-EA		extra thick 'A'	50/box	FCFGA600-Ni-EA		extra thick 'A'	50/box
FCFGA600-Cu-EB		extra thick 'B'	50/box	FCFGA600-Ni-EB		extra thick 'B'	50/box
FCFGA600-Cu-EC	extra thick 'C'	50/box	FCFGA600-Ni-EC	extra thick 'C'	50/box		
FCFGA800-Cu-SB	800 micron	standard 'B'	50/box	FCFGA800-Ni-SB	800 micron	standard 'B'	50/box
FCFGA800-Cu-SC		standard 'C'	50/box	FCFGA800-Ni-SC		standard 'C'	50/box
FCFGA800-Cu-UA		ultra-thin 'A'	50/box	FCFGA800-Ni-UA		ultra-thin 'A'	50/box
FCFGA800-Cu-UB		ultra-thin 'B'	50/box	FCFGA800-Ni-UB		ultra-thin 'B'	50/box
FCFGA800-Cu-UC		ultra-thin 'C'	50/box	FCFGA800-Ni-UC		ultra-thin 'C'	50/box
FCFGA800-Cu-TA		thick 'A'	50/box	FCFGA800-Ni-TA		thick 'A'	50/box
FCFGA800-Cu-TB		thick 'B'	50/box	FCFGA800-Ni-TB		thick 'B'	50/box
FCFGA800-Cu-TC		thick 'C'	50/box	FCFGA800-Ni-TC		thick 'C'	50/box
FCFGA800-Cu-EA		extra thick 'A'	50/box	FCFGA800-Ni-EA		extra thick 'A'	50/box
FCFGA800-Cu-EB		extra thick 'B'	50/box	FCFGA800-Ni-EB		extra thick 'B'	50/box
FCFGA800-Cu-EC	extra thick 'C'	50/box	FCFGA800-Ni-EC	extra thick 'C'	50/box		
FCFGA1000-Cu-SB	1000 micron	standard 'B'	50/box	FCFGA1000-Ni-SB	1000 micron	standard 'B'	50/box
FCFGA1000-Cu-SC		standard 'C'	50/box	FCFGA1000-Ni-SC		standard 'C'	50/box
FCFGA1000-Cu-UA		ultra-thin 'A'	50/box	FCFGA1000-Ni-UA		ultra-thin 'A'	50/box
FCFGA1000-Cu-UB		ultra-thin 'B'	50/box	FCFGA1000-Ni-UB		ultra-thin 'B'	50/box
FCFGA1000-Cu-UC		ultra-thin 'C'	50/box	FCFGA1000-Ni-UC		ultra-thin 'C'	50/box
FCFGA1000-Cu-TA		thick 'A'	50/box	FCFGA1000-Ni-TA		thick 'A'	50/box
FCFGA1000-Cu-TB		thick 'B'	50/box	FCFGA1000-Ni-TB		thick 'B'	50/box
FCFGA1000-Cu-TC		thick 'C'	50/box	FCFGA1000-Ni-TC		thick 'C'	50/box
FCFGA1000-Cu-EA		extra thick 'A'	50/box	FCFGA1000-Ni-EA		extra thick 'A'	50/box
FCFGA1000-Cu-EB		extra thick 'B'	50/box	FCFGA1000-Ni-EB		extra thick 'B'	50/box
FCFGA1000-Cu-EC	extra thick 'C'	50/box	FCFGA1000-Ni-EC	extra thick 'C'	50/box		
FCFGA1500-Cu-SB	1500 micron	standard 'B'	50/box	FCFGA1500-Ni-SB	1500 micron	standard 'B'	50/box
FCFGA1500-Cu-SC		standard 'C'	50/box	FCFGA1500-Ni-SC		standard 'C'	50/box
FCFGA1500-Cu-UA		ultra-thin 'A'	50/box	FCFGA1500-Ni-UA		ultra-thin 'A'	50/box
FCFGA1500-Cu-UB		ultra-thin 'B'	50/box	FCFGA1500-Ni-UB		ultra-thin 'B'	50/box
FCFGA1500-Cu-UC		ultra-thin 'C'	50/box	FCFGA1500-Ni-UC		ultra-thin 'C'	50/box
FCFGA1500-Cu-TA		thick 'A'	50/box	FCFGA1500-Ni-TA		thick 'A'	50/box
FCFGA1500-Cu-TB		thick 'B'	50/box	FCFGA1500-Ni-TB		thick 'B'	50/box
FCFGA1500-Cu-TC		thick 'C'	50/box	FCFGA1500-Ni-TC		thick 'C'	50/box
FCFGA1500-Cu-EA		extra thick 'A'	50/box	FCFGA1500-Ni-EA		extra thick 'A'	50/box
FCFGA1500-Cu-EB		extra thick 'B'	50/box	FCFGA1500-Ni-EB		extra thick 'B'	50/box
FCFGA1500-Cu-EC	extra thick 'C'	50/box	FCFGA1500-Ni-EC	extra thick 'C'	50/box		

III Formvar/Silicon Monoxide

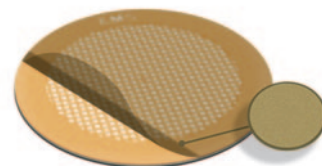
A formvar film stabilized with a thin film of Silicon Monoxide. Silicon Monoxide produces a desirable support film because it offers low background contrast and it is stable under the electron beam and it is more hydrophilic than carbon film.



Cat. #	Type	Qty	Cat. #	Type	Qty
FSF200-Cu	200 mesh	50/box	FSF200-Ni	200 mesh	50/box
FSF300-Cu	300 mesh	50/box	FSF300-Ni	300 mesh	50/box
FSF400-Cu	400 mesh	50/box	FSF400-Ni	400 mesh	50/box

III Silicon Monoxide Film Only

A thin film of pure Silicon Monoxide (15–30 nm) is deposited directly on top of the grid.

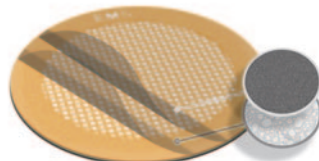
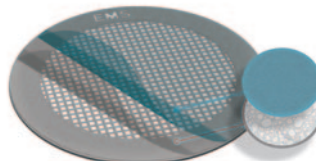
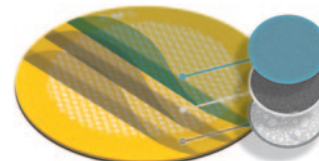


Cat. #	Type	Qty	Cat. #	Type	Qty
SF200-Cu	200 mesh	50/box	SF200-Ni	200 mesh	50/box
SF300-Cu	300 mesh	50/box	SF300-Ni	300 mesh	50/box
SF400-Cu	400 mesh	50/box	SF400-Ni	400 mesh	50/box

SUPPORT FILM ON GRIDS



Holey Carbon

Holey Carbon with
Continuous Ultrathin CarbonHoley Carbon with Continuous
Ultrathin FormvarHoley Carbon with
Continuous Ultrathin Carbon
and Formvar

III Holey Carbon Film

A thin piece of carbon. The average hole sizes are 50, 100 and 150 nm.

Cat. #	Type	Qty
HC200-Cu	200 MESH	25/box
HC300-Cu	300 MESH	25/box
HC400-Cu	400 MESH	25/box

Cat. #	Type	Qty
HC200-Ni	200 MESH	25/box
HC300-Ni	300 MESH	25/box
HC400-Ni	400 MESH	25/box

Cat. #	Type	Qty
HC200-Au	200 MESH	25/box
HC300-Au	300 MESH	25/box
HC400-Au	400 MESH	25/box

Cat. #	Type	Hole Size	Qty
HC200-Cu-100	200 MESH	100 nm	25/box
HC200-Cu-150		150 nm	25/box
HC300-Cu-100	300 MESH	100 nm	25/box
HC300-Cu-150		150 nm	25/box
HC400-Cu-100	400 MESH	100 nm	25/box
HC400-Cu-150		150 nm	25/box

Cat. #	Type	Hole Size	Qty
HC200-Ni-100	200 MESH	100 nm	25/box
HC200-Ni-150		150 nm	25/box
HC300-Ni-100	300 MESH	100 nm	25/box
HC300-Ni-150		150 nm	25/box
HC400-Ni-100	400 MESH	100 nm	25/box
HC400-Ni-150		150 nm	25/box

Cat. #	Type	Hole Size	Qty
HC200-Au-100	200 MESH	100 nm	25/box
HC200-Au-150		150 nm	25/box
HC300-Au-100	300 MESH	100 nm	25/box
HC300-Au-150		150 nm	25/box
HC400-Au-100	400 MESH	100 nm	25/box
HC400-Au-150		150 nm	25/box

Ultrathin

Cat. #	Type	Thickness	Qty
HC200-Cu-UL	200 MESH	4-6 nm	25/box
HC300-Cu-UL	300 MESH	4-6 nm	25/box
HC400-Cu-UL	400 MESH	4-6 nm	25/box

Cat. #	Type	Thickness	Qty
HC200-Ni-UL	200 MESH	4-6 nm	25/box
HC300-Ni-UL	300 MESH	4-6 nm	25/box
HC400-Ni-UL	400 MESH	4-6 nm	25/box

Cat. #	Type	Thickness	Qty
HC200-Au-UL	200 MESH	4-6 nm	25/box
HC300-Au-UL	300 MESH	4-6 nm	25/box
HC400-Au-UL	400 MESH	4-6 nm	25/box

Continuous Ultrathin Films

The continuous ultrathin film on holey film allows for the thinnest support film that still has adequate strength to withstand specimen preparation. The film (less than 3nm thick) lies across a carbon lacey film supported by a 200, 300, or 400 mesh grid. The size of the holes in the holey film differ widely from batch to batch but are generally in the range of 1/4 μm to 5μm, which gives the equivalent support of at least 6000 mesh grid. Specimen material lying over the covered holes can be imaged in the TEM with practically no interference from the carbon film supporting it. This product is ideal for looking at nanotubes, virus particles and other small particulate material.

III Holey Carbon Film with a Continuous Layer of Ultrathin Carbon Film

Continuous Layer Thickness: Carbon — less than 3 nm.

Cat. #	Type	Qty
HC200-Cu-CC	200 MESH	25/box
HC300-Cu-CC	300 MESH	25/box
HC400-Cu-CC	400 MESH	25/box

Cat. #	Type	Qty
HC200-Ni-CC	200 MESH	25/box
HC300-Ni-CC	300 MESH	25/box
HC400-Ni-CC	400 MESH	25/box

Cat. #	Type	Qty
HC200-Au-CC	200 MESH	25/box
HC300-Au-CC	300 MESH	25/box
HC400-Au-CC	400 MESH	25/box

III Holey Carbon Film with a Continuous Layer of Ultrathin Formvar Film

Continuous Layer Thickness: Formvar — 3-4 nm.

Cat. #	Type	Qty
HC200-Cu-FF	200 MESH	25/box
HC300-Cu-FF	300 MESH	25/box
HC400-Cu-FF	400 MESH	25/box

Cat. #	Type	Qty
HC200-Ni-FF	200 MESH	25/box
HC300-Ni-FF	300 MESH	25/box
HC400-Ni-FF	400 MESH	25/box

Cat. #	Type	Qty
HC200-Au-FF	200 MESH	25/box
HC300-Au-FF	300 MESH	25/box
HC400-Au-FF	400 MESH	25/box

III Holey Carbon Film with a Continuous Layer of Ultrathin Carbon and Formvar Film

Continuous Layer Thickness: Carbon 1 nm, Formvar 5 nm.

Cat. #	Type	Qty
HC200-Cu-FCF	200 MESH	25/box
HC300-Cu-FCF	300 MESH	25/box
HC400-Cu-FCF	400 MESH	25/box

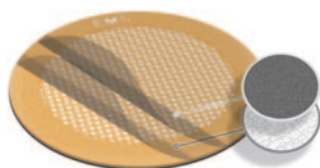
Cat. #	Type	Qty
HC200-Ni-FCF	200 MESH	25/box
HC300-Ni-FCF	300 MESH	25/box
HC400-Ni-FCF	400 MESH	25/box

Cat. #	Type	Qty
HC200-Au-FCF	200 MESH	25/box
HC300-Au-FCF	300 MESH	25/box
HC400-Au-FCF	400 MESH	25/box

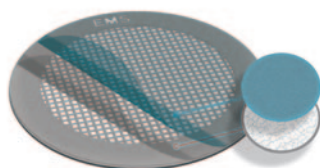
SUPPORT FILM ON GRIDS



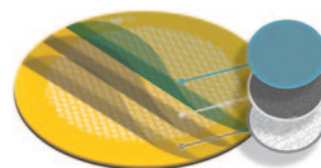
Lacey Carbon



Lacey Carbon with Continuous Ultrathin Carbon



Lacey Carbon with Continuous Ultrathin Formvar



Lacey Carbon with Continuous Ultrathin Carbon and Formvar

III Lacey Carbon Film

This carbon coated film on a broken pattern consists of woven-mesh-like holes of different sizes and shapes. This type of pattern provides support but does not interfere when observing specimen sections.

Cat. #	Type	Hole Size	Qty	Cat. #	Type	Hole Size	Qty	Cat. #	Type	Hole Size	Qty
LC200-Cu	200 MESH	50 nm	5/box	LC200-Ni	200 MESH	50 nm	5/box	LC200-Au	200 MESH	50 nm	5/box
LC200-Cu-25			25/box	LC200-Ni-25			25/box	LC200-Au-25			25/box
LC300-Cu	300 MESH	50 nm	5/box	LC305-Ni	300 MESH	50 nm	5/box	LC300-Au	300 MESH	50 nm	5/box
LC325-Cu			25/box	LC325-Ni			25/box	LC325-Au			25/box
LC400-Cu	400 MESH	50 nm	5/box	LC400-Ni	400 MESH	50 nm	5/box	LC400-Au	400 MESH	50 nm	5/box
LC400-Cu-25			25/box	LC400-Ni-25			25/box	LC400-Au-25			25/box

Cat. #	Type	Hole Size	Qty	Cat. #	Type	Hole Size	Qty	Cat. #	Type	Hole Size	Qty
LC200-Cu-100	200 MESH	100 nm	25/box	LC200-Ni-100	200 MESH	100 nm	25/box	LC200-Au-100	200 MESH	100 nm	25/box
LC200-Cu-150		150 nm	25/box	LC200-Ni-150		150 nm	25/box	LC200-Au-150		150 nm	25/box
LC300-Cu-100	300 MESH	100 nm	25/box	LC300-Ni-100	300 MESH	100 nm	25/box	LC300-Au-100	300 MESH	100 nm	25/box
LC300-Cu-150		150 nm	25/box	LC300-Ni-150		150 nm	25/box	LC300-Au-150		150 nm	25/box
LC400-Cu-100	400 MESH	100 nm	25/box	LC400-Ni-100	400 MESH	100 nm	25/box	LC400-Au-100	400 MESH	100 nm	25/box
LC400-Cu-150		150 nm	25/box	LC400-Ni-150		150 nm	25/box	LC400-Au-150		150 nm	25/box

Ultrathin

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
LC200-Cu-UL	200 MESH	4-6 nm	25/box	LC200-Ni-UL	200 MESH	4-6 nm	25/box	LC200-Au-UL	200 MESH	4-6 nm	25/box
LC300-Cu-UL			300 MESH	4-6 nm			25/box	LC300-Ni-UL			300 MESH
LC400-Cu-UL	400 MESH	4-6 nm	25/box	LC400-Ni-UL	400 MESH	4-6 nm	25/box	LC400-Au-UL	400 MESH	4-6 nm	25/box

Continuous Ultrathin Films

The continuous ultrathin film on lacey film allows for the thinnest support film that still has adequate strength to withstand specimen preparation. The film (less than 3nm thick) lies across a carbon lacey film supported by a 200, 300, or 400 mesh grid. The size of the holes in the lacey film differ widely from batch to batch but are generally in the range of ¼ µm to 5µm, which gives the equivalent support of at least 6000 mesh grid. Specimen material lying over the covered holes can be imaged in the TEM with practically no interference from the carbon film supporting it. This product is ideal for looking at nanotubes, virus particles and other small particulate material.

III Lacey Carbon Film with a Continuous Layer of Ultrathin Carbon Film

Continuous Layer Thickness: Carbon — less than 3 nm.

Cat. #	Type	Hole Size	Qty	Cat. #	Type	Hole Size	Qty	Cat. #	Type	Hole Size	Qty
LC200-Cu-CC	200 MESH	5 micron	5/box	LC200-Ni-CC	200 MESH	5 micron	5/box	LC200-Au-CC	200 MESH	5 micron	5/box
LC200-Cu-CC-25			25/box	LC200-Ni-CC-25			25/box	LC200-Au-CC-25			25/box
LC300-Cu-CC	300 MESH	5 micron	5/box	LC305-Ni-CC	300 MESH	5 micron	5/box	LC300-Au-CC	300 MESH	5 micron	5/box
LC325-Cu-CC			25/box	LC325-Ni-CC			25/box	LC325-Au-CC			25/box
LC400-Cu-CC	400 MESH	5 micron	5/box	LC400-Ni-CC	400 MESH	5 micron	5/box	LC400-Au-CC	400 MESH	5 micron	5/box
LC400-Cu-CC-25			25/box	LC400-Ni-CC-25			25/box	LC400-Au-CC-25			25/box

III Lacey Carbon Film with a Continuous Layer of Ultrathin Formvar Film

Continuous Layer Thickness: Formvar — 3-4 nm.

Cat. #	Type	Hole Size	Qty	Cat. #	Type	Hole Size	Qty	Cat. #	Type	Hole Size	Qty
LC200-Cu-FF	200 MESH	5 micron	5/box	LC200-Ni-FF	200 MESH	5 micron	5/box	LC200-Au-FF	200 MESH	5 micron	5/box
LC200-Cu-FF-25			25/box	LC200-Ni-FF-25			25/box	LC200-Au-FF-25			25/box
LC300-Cu-FF	300 MESH	5 micron	5/box	LC305-Ni-FF	300 MESH	5 micron	5/box	LC300-Au-FF	300 MESH	5 micron	5/box
LC325-Cu-FF			25/box	LC325-Ni-FF			25/box	LC325-Au-FF			25/box
LC400-Cu-FF	400 MESH	5 micron	5/box	LC400-Ni-FF	400 MESH	5 micron	5/box	LC400-Au-FF	400 MESH	50 micron	5/box
LC400-Cu-FF-25			25/box	LC400-Ni-FF-25			25/box	LC400-Au-FF-25			25/box

||| Lacey Carbon Film (continued)

||| Lacey Carbon Film with a Continuous Layer of Ultrathin Carbon and Formvar Film

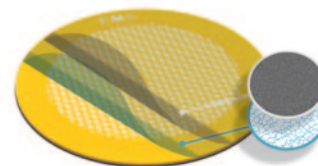
Continuous Layer Thickness: Carbon — 1 nm, Formvar — 5 nm.

Cat. #	Type	Hole Size	Qty	Cat. #	Type	Hole Size	Qty	Cat. #	Type	Hole Size	Qty
LC200-Cu-FCF	200 MESH	5 micron	5/box	LC200-Ni-FCF	200 MESH	5 micron	5/box	LC200-Au-FCF	200 MESH	5 micron	5/box
LC200-Cu-FCF-25			25/box	LC200-Ni-FCF-25			25/box	LC200-Au-FCF-25			25/box
LC300-Cu-FCF	300 MESH	5 micron	5/box	LC305-Ni-FCF	300 MESH	5 micron	5/box	LC300-Au-FCF	300 MESH	5 micron	5/box
LC325-Cu-FCF			25/box	LC325-Ni-FCF			25/box	LC325-Au-FCF			25/box
LC400-Cu-FCF	400 MESH	5 micron	5/box	LC400-Ni-CFF	400 MESH	5 micron	5/box	LC400-Au-FCF	400 MESH	5 micron	5/box
LC400-Cu-FCF-25			25/box	LC400-Ni-FCF-25			25/box	LC400-Au-FCF-25			25/box

||| Tomography Grids with Carbon or Lacey Carbon Support Film...see page 15

||| Lacey Formvar with Carbon Film

This formvar and carbon coated film on a broken pattern consists of woven-mesh-like holes of different sizes and shapes. Average hole sizes are 50, 100 and 150 microns. This type of pattern provides support but does not interfere when observing specimen sections.



Cat. #	Type	Hole Size	Qty	Cat. #	Type	Hole Size	Qty	Cat. #	Type	Hole Size	Qty
LFC200-Cu-50	200 MESH	50 nm	25/bx	LFC200-Ni-50	200 MESH	50 nm	25/bx	LFC200-Au-50	200 MESH	50 nm	25/bx
LFC200-Cu-100		100 nm	25/bx	LFC200-Ni-100		100 nm	25/bx	LFC200-Au-100		100 nm	25/bx
LFC200-Cu-150		150 nm	25/bx	LFC200-Ni-150		150 nm	25/bx	LFC200-Au-150		150 nm	25/bx
LFC300-Cu-50	300 MESH	50 nm	25/bx	LFC300-Ni-50	300 MESH	50 nm	25/bx	LFC300-Au-50	300 MESH	50 nm	25/bx
LFC300-Cu-100		100 nm	25/bx	LFC300-Ni-100		100 nm	25/bx	LFC300-Au-100		100 nm	25/bx
LFC300-Cu-150		150 nm	25/bx	LFC300-Ni-150		150 nm	25/bx	LFC300-Au-150		150 nm	25/bx
LFC400-Cu-50	400 MESH	50 nm	25/bx	LFC400-Ni-50	400 MESH	50 nm	25/bx	LFC400-Au-50	400 MESH	50 nm	25/bx
LFC400-Cu-100		100 nm	25/bx	LFC400-Ni-100		100 nm	25/bx	LFC400-Au-100		100 nm	25/bx
LFC400-Cu-150		150 nm	25/bx	LFC400-Ni-150		150 nm	25/bx	LFC400-Au-150		150 nm	25/bx

||| Pioloform Film

A thin film of Pioloform deposited on one side of the grid.

EMS is proud to introduce a new line of coated grids made with Pioloform, which offers the advantage of higher thermal stability, as well as mechanical stability, over Formvar. These coated grids have no carbon layer and offer less electron scattering. *NOTE: All of our film is laid on the shiny side of the grid.*

- 3.05mm grids in Au, Ni, and Cu.
- Available in 25/pack grid storage boxes.
- 6 mesh sizes: 75 Mesh, 100 Mesh, 200 Mesh, 300 Mesh, 400 Mesh, and 2 x 1mm.

Standard Thickness, approx. 5–6 nm

Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty	Cat. #	Type	Thickness	Qty
Pi-75-Cu-25	75 MESH	standard	25/box	Pi-75-Ni-25	75 MESH	standard	25/box	Pi-75-Au-25	75 MESH	standard	25/box
Pi-100-Cu-25	100 MESH	standard	25/box	Pi-100-Ni-25	100 MESH	standard	25/box	Pi-100-Au-25	100 MESH	standard	25/box
Pi-200-Cu-25	200 MESH	standard	25/box	Pi-200-Ni-25	200 MESH	standard	25/box	Pi-200-Au-25	200 MESH	standard	25/box
Pi-300-Cu-25	300 MESH	standard	25/box	Pi-300-Ni-25	300 MESH	standard	25/box	Pi-300-Au-25	300 MESH	standard	25/box
Pi-400-Cu-25	400 MESH	standard	25/box	Pi-400-Ni-25	400 MESH	standard	25/box	Pi-400-Au-25	400 MESH	standard	25/box
Pi-2010-Cu-25	2 x 1mm	standard	25/box	Pi-2010-Ni-25	2 x 1mm	standard	25/box	Pi-2010-Au-25	2 x 1mm	standard	25/box

||| Beryllium Support Films

A deposition of 250 Angstroms thick Beryllium onto the 0.005" thick, 25x25mm squares of a Cu substrate. The Be can be removed by dissolving the substrate in nitric acid (50:50). The Be film will then be removed from the acid, washed in distilled water and mounted on TEM grids. A Be support film will reduce background interference to a minimum and it is particularly useful where analyses for C or Si are required, so that these alternative supports cannot be used. Another advantage of the Be support is its very fine grain size which produces a very sharp ring pattern for in-situ calibration.

Cat #	Description	Qty
76030	Beryllium Support Film, 25x25mm	each



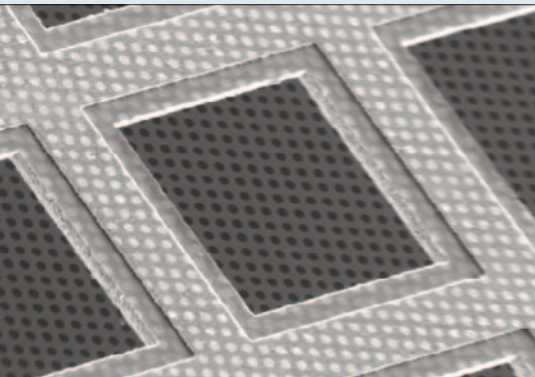
TEM SUPPORT FILMS

The C-flat™ Family

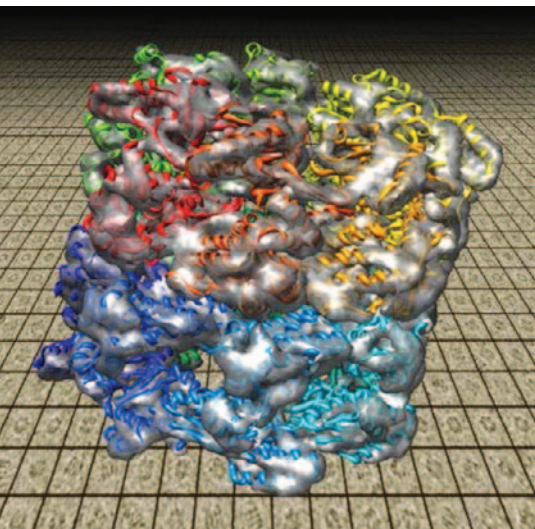
Holey Carbon, Gold Grids for S/TEM and Cryo-TEM...
now by EMS.

Electron Microscopy Sciences is pleased to announce the acquisition of the C-flat™, Au-flat™, and CD-flat™ product lines, which can be purchased directly from EMS effective immediately.

We are excited to continue to offer and expand on the C-flat line and look forward to working with all our current and new customers in the years ahead.



Below: 250,000 particles of GroEL in 24 hours. Image Courtesy of Scott Stagg and Mike Pique NRAMM, The Scripps Research Institute (data acquired on CF-2/2-4C)



The C-flat™ Advantage

C-flat™ is an ultra-flat, holey carbon-coated TEM support grid for transmission electron microscopy (TEM). Unlike competing holey carbon films, C-flat™ is manufactured without plastics, so it is clean upon arrival and the user has no residue to contend with.

C-flat™ leads to better data sets.

Made with patented technology, C-flat™ provides an ultra-flat surface that results in better particle dispersion and more uniform ice thickness. Patterning is done using deep-UV projection lithography, ensuring the most accurate and consistent hole shapes and sizes down to submicron features. The precise methods by which C-flat™ is manufactured eliminate artifacts such as excess carbon and edges around holes.

C-flat™ is affordable

C-flat™ is available in 25, 50, and 100 packs at a per-grid price less than competing products. *With 54 varieties, there is always a C-flat™ product optimized for your needs.*

Applications

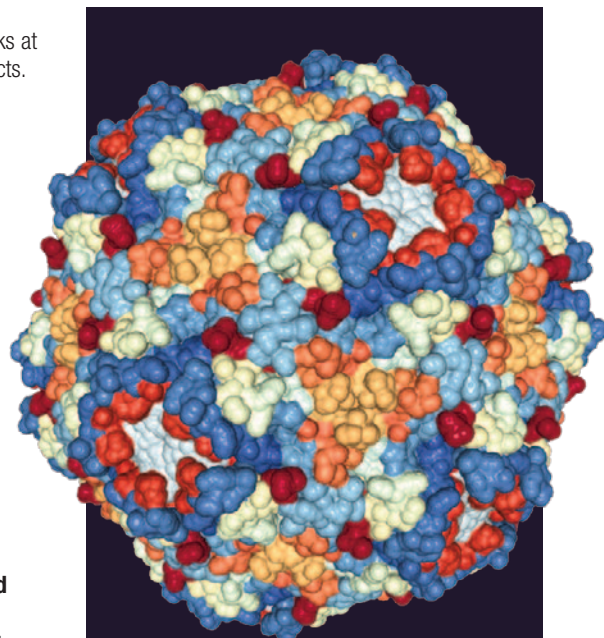
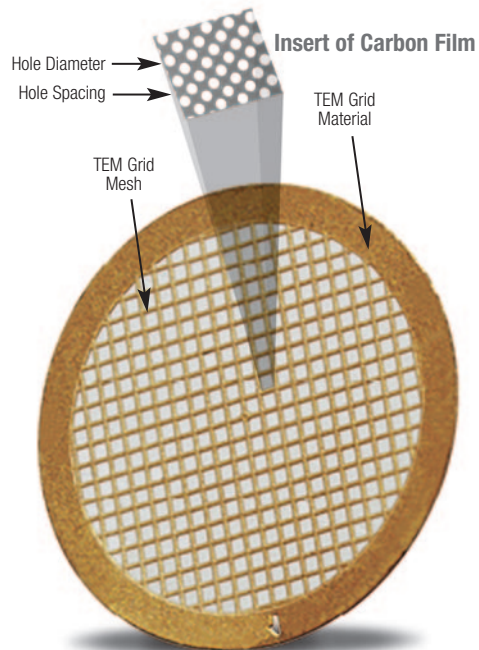
The perfect choice for...

- Single particle analysis
- Cryo electron tomography
- Automated TEM workflow

C-flat™ holey carbon grids provide the ideal specimen support to achieve high resolution data in cryo-TEM making them an ideal choice for single particle analysis, cryo electron tomography and automated TEM analysis.

Cryo-electron tomography (cryoET) and Single Particle Analysis (SPA):

Numerous researchers have reported that the ultra-flat surface of C-flat™ leads to even ice thickness and uniform particle distribution within the hole areas. This optimal particle distribution results in superior data being collected as compared with other holey support films. 2µm hole sizes are standard but custom

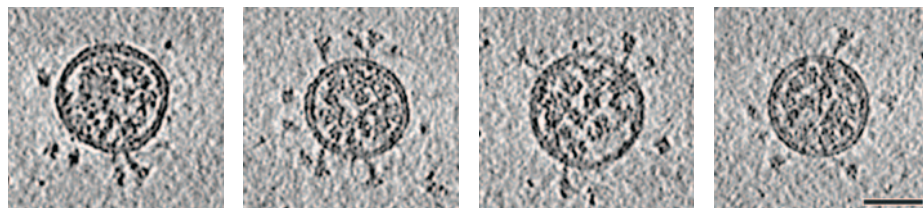


2.9 Angstrom Resolution Cryo-EM 3-D Reconstruction of Close-packed PCV2 Virus-like Particles
PDB ID: 3JCI Liu, Z., Guo, F., Wang, F., Li, T.C., Jiang, W. (2016) Structure 24: 319-328

C-flat™ Family of Holey Carbon, Gold Grids for S/TEM and Cryo-TEM (continued)

C-flat™ (continued)

The premier holey carbon grid for cryo-transmission electron microscopy



Above: Cryo-ET using C-flat 2/2 hole pattern on Covid 19 Spike Protein. Ke, Z., Oton, J., Qu, K. et al. Structures and distributions of SARS-CoV-2 spike proteins on intact virions. Nature (2020). <https://doi.org/10.1038/s41586-020-2665-2>

hole sizes are available so C-flat™ can accommodate the common magnifications used for quantitative TEM analysis.

Automated TEM:

C-flat™ provides a regular array of analysis sites compatible with automated data collection software such as Leginon. This compatibility, in combination with the more uniform ice thickness and particle distribution reported by numerous researchers, results in more high-quality target sites per grid.

Publications using C-flat™:

Near-atomic resolution using electron cryomicroscopy and single-particle reconstruction. Proceedings of the National Academy of Sciences, Volume 105, Number 6, pp. 1867-1872, 2008. X. Zhang, E. Settembre, C. Xu, P. R. Dormitzer, R. Bellamy, S. C. Harrison, and N. Grigorieff

Preparation of macromolecular complexes for cryo-electron microscopy. Nature Protocols, Volume 2, pp. 3239 - 3246, 2007. R. A. Grassucci, D. J. Taylor, and J. Frank

Segrosome structure revealed by a complex of ParR with centromere DNA. Nature, Volume 450, pp. 1268-1271, 2007. M. A. Schumacher, T. C. Glover, A. J. Brzoska, S. O. Jensen, T. D. Dunham, R. A. Skurray and N. Firth

Automation of random canonical tilt and orthogonal tilt data collection using feature-based correlation. Journal of Structural Biology, Volume 159, Issue 3, pp. 335-346, September 2007. C. Yoshioka, J. Pulokas, D. Fellmann, C. S. Potter, R. A. Milligan and B. Carragher

Automated cryoEM data acquisition and analysis of 284 742 particles of GroEL. Journal of Structural Biology, Volume 155, Issue 3, pp. 470-481, September 2006. S. M. Stagg, G. C. Lander, J. Pulokas, D. S. Fellmann, A. Cheng, J. D. Quispe, S. P. Mallick, R. M. Avila, B. Carragher and C. S. Potter

Contamination buildup limit throughput for automated cryoEM? Journal of Structural Biology, Volume 154, Issue 3, pp. 303-311, June 2006. A. Cheng, D. Fellmann, J. Pulokas, C. S. Potter and B. Carragher

Articles

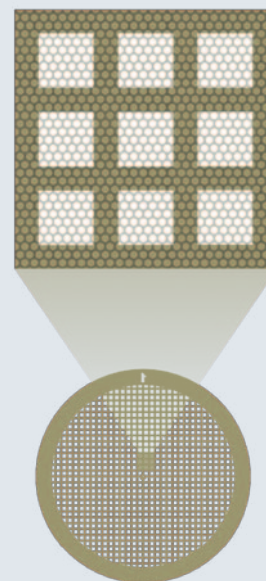
Cryo-EM structure of the 2019-nCoV spike in the prefusion conformation. Daniel Wrapp, Nianshuang Wang, Kizzmekia S. Corbett, Jory A. Goldsmith, Ching-Lin Hsieh, Olubukola Abiona, Barney S. Graham, Jason S. McLellan, 2020. Science, 13 Mar 2020: Vol. 367, Issue 6483, pp. 1260-1263, DOI: 10.1126/science.abb2507

An improved holey carbon film for cryo-electron microscopy. Quispe J, Damiano J, Mick SE, Nackashi DP, Fellmann D, Ajero TG, Carragher B, Potter CS, (2007). Microscopy and microanalysis, 13(5), 365-371.

Improving the technique of vitreous cryo-sectioning for cryo-electron tomography: electrostatic charging for section attachment and implementation of an anti-contamination glove box. Pierson J, Fernández JJ, Bos E, Amiri S, Gnaegi H, Vos M, Bel B, Adolfsen F, Carrascosa JL, Peters P.J., J Struct Biol. 2010 Feb;169(2): 219-25. Epub 2009 Oct 12.

CD-flat™ for Automated S/TEM Imaging and Metrology

The C-flat™ advantage in a new pattern



CD-flat™ — the premier ultra-flat holey carbon grid is ready to use with no additional cleaning or handling steps, and is now available, featuring a NEW 8/2 hole pattern. CD-flat is designed for CD-TEM metrology of large specimens, like 3D NAND FIB lamella.

Specifications

Grid Material	Copper
Mesh Size	300 Mesh
O.D.	3.05mm
Film Material	Holey Carbon
Film Thickness	40nm
Hole Pattern	8/2 (8 um diameter, 2 μ spacing between holes)

Ordering Information

Product Code	Cat. #	Qty.
CDF-8/2-3Cu-T-50	CDFT823-50	50/pk

TEM SUPPORT FILMS

C-flat™ Family of Holey Carbon, Gold Grids for S/TEM and Cryo-TEM (continued)

Standard Products

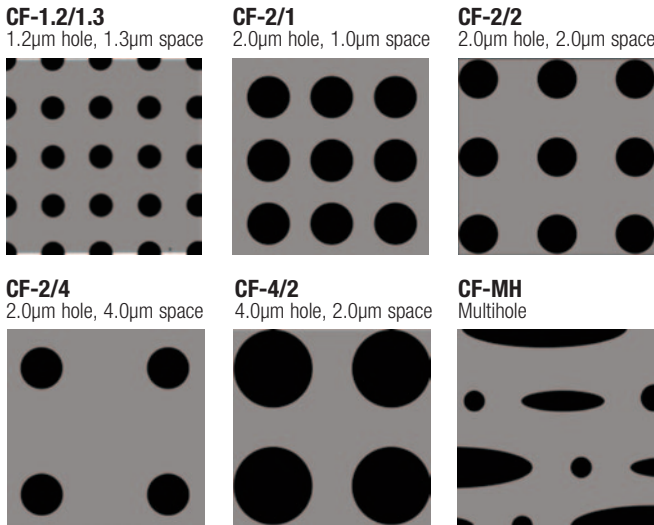
The breadth of applications in cryoTEM necessitate a wide range of holey carbon film patterns. And now, with the recent expansion of the product line, a C-flat™ holey carbon film is available for almost any application. Whether 600nm holes are needed for very high magnifications with ultra-high resolution cameras or large open areas are needed for larger specimens, C-Flat™ is the perfect holey carbon grid.

C-flat™ is immediately available in several standard array patterns including hole diameters/hole spacings of 1.2/1.3, 2/1, 2/2, 2/4, 4/2, and a multihole pattern. C-flat™ is supported by your choice of a 200 mesh 300 mesh, or 400 mesh copper TEM grid and sold in quantities of 25, 50, or 100.

Thick Products

C-flat™ is available in a thick option that doubles the carbon thickness from approximately 20nm to 40nm. Thick C-flat product numbers end in -T, catalog numbers contain "CFT". Available in quantities of 50 and 100 per pack.

Standard Array Patterns



NEW Trial Sizes!

C-flat Holey Carbon on Copper or Gold and C-flat Thick Option on Copper

Not sure if C-flat is right for your application? Now you can try it out with a trial size of 10 per pack in our most popular sizes and types! See the special ordering table below. **Thick version indicated with a "-T."**

Product Code	Cat. #	Hole Size	Hole Spacing	TEM Mesh	TEM Grid	Qty.
CF-1.2/1.3-2C	CF213-10	1.2 µm	1.3 µm	200	Cu	10/pk
CF-1.2/1.3-2C-T	CFT213-10	1.2 µm	1.3 µm	200	Cu	10/pk
CF-1.2/1.3-2Au	CF213-10-Au	1.2 µm	1.3 µm	200	Au	10/pk
CF-1.2/1.3-3C	CF313-10	1.2 µm	1.3 µm	300	Cu	10/pk
CF-1.2/1.3-3C-T	CFT313-10	1.2 µm	1.3 µm	300	Cu	10/pk
CF-1.2/1.3-3Au	CF313-10-Au	1.2 µm	1.3 µm	300	Au	10/pk
CF-2/2-2C	CF-222C-10	2.0 µm	2.0 µm	200	Cu	10/pk
CF-2/2-2C-T	CFT-222C-10	2.0 µm	2.0 µm	200	Cu	10/pk
CF-2/2-2Au	CF-222C-10-Au	2.0 µm	2.0 µm	200	Au	10/pk
CF-2/2-3C	CF-223C-10	2.0 µm	2.0 µm	300	Cu	10/pk
CF-2/2-3C-T	CFT-223C-10	2.0 µm	2.0 µm	300	Cu	10/pk
CF-2/2-3Au	CF-223C-10-Au	2.0 µm	2.0 µm	300	Au	10/pk

Ordering Guide

C-flat™ Holey Carbon Grids for TEM

Copper Only

Product Code	Cat. #	Hole Size	Hole Spacing	TEM Mesh	TEM Grid	Qty.
CF-1.2/1.3-2C	CF213-25	1.2 µm	1.3 µm	200	Cu	25/pk.
	CF213-50	1.2 µm	1.3 µm	200	Cu	50/pk.
	CF213-100	1.2 µm	1.3 µm	200	Cu	100/pk.
CF-1.2/1.3-3C	CF313-25	1.2 µm	1.3 µm	300	Cu	25/pk.
	CF313-50	1.2 µm	1.3 µm	300	Cu	50/pk.
	CF313-100	1.2 µm	1.3 µm	300	Cu	100/pk.
CF-1.2/1.3-4C	CF413-25	1.2 µm	1.3 µm	400	Cu	25/pk.
	CF413-50	1.2 µm	1.3 µm	400	Cu	50/pk.
	CF413-100	1.2 µm	1.3 µm	400	Cu	100/pk.
CF-2/1-2C	CF212-25	2.0 µm	1.0 µm	200	Cu	25/pk.
	CF212-50	2.0 µm	1.0 µm	200	Cu	50/pk.
	CF212-100	2.0 µm	1.0 µm	200	Cu	100/pk.
CF-2/1-3C	CF312-25	2.0 µm	1.0 µm	300	Cu	25/pk.
	CF312-50	2.0 µm	1.0 µm	300	Cu	50/pk.
	CF312-100	2.0 µm	1.0 µm	300	Cu	100/pk.
CF-2/1-4C	CF412-25	2.0 µm	1.0 µm	400	Cu	25/pk.
	CF412-50	2.0 µm	1.0 µm	400	Cu	50/pk.
	CF412-100	2.0 µm	1.0 µm	400	Cu	100/pk.
CF-2/2-2C	CF-222C-25	2.0 µm	2.0 µm	200	Cu	25/pk.
	CF-222C-50	2.0 µm	2.0 µm	200	Cu	50/pk.
	CF-222C-100	2.0 µm	2.0 µm	200	Cu	100/pk.
CF-2/2-3C	CF-322C-25	2.0 µm	2.0 µm	300	Cu	25/pk.
	CF-322C-50	2.0 µm	2.0 µm	300	Cu	50/pk.
	CF-322C-100	2.0 µm	2.0 µm	300	Cu	100/pk.
CF-2/2-4C	CF-224C-50	2.0 µm	2.0 µm	400	Cu	50/pk.
	CF-224C-100	2.0 µm	2.0 µm	400	Cu	100/pk.
CF-2/4-2C	CF242-50	2.0 µm	4.0 µm	200	Cu	50/pk.
	CF242-100	2.0 µm	4.0 µm	200	Cu	100/pk.
CF-2/4-3C	CF342-25	2.0 µm	4.0 µm	300	Cu	25/pk.
	CF342-50	2.0 µm	4.0 µm	300	Cu	50/pk.
	CF342-100	2.0 µm	4.0 µm	300	Cu	100/pk.
CF-2/4-4C	CF442-25	2.0 µm	4.0 µm	400	Cu	25/pk.
	CF442-50	2.0 µm	4.0 µm	400	Cu	50/pk.
	CF442-100	2.0 µm	4.0 µm	400	Cu	100/pk.
CF-4/2-2C	CF422-25	4.0 µm	2.0 µm	200	Cu	25/pk.
	CF422-50	4.0 µm	2.0 µm	200	Cu	50/pk.
	CF422-100	4.0 µm	2.0 µm	200	Cu	100/pk.
CF-4/2-3C	CF423-50	4.0 µm	2.0 µm	300	Cu	50/pk.
	CF423-100	4.0 µm	2.0 µm	300	Cu	100/pk.
CF-4/2-4C	CF424-50	4.0 µm	2.0 µm	400	Cu	50/pk.
	CF424-100	4.0 µm	2.0 µm	400	Cu	100/pk.
CF-MH-2C	CF2MH-50	Multihole*		200	Cu	50/pk.
	CF2MH-100	Multihole*		200	Cu	100/pk.
CF-MH-3C	CF3MH-25	Multihole*		300	Cu	25/pk.
	CF3MH-50	Multihole*		300	Cu	50/pk.
	CF3MH-100	Multihole*		300	Cu	100/pk.
CF-MH-4C	CF4MH-25	Multihole*		400	Cu	25/pk.
	CF4MH-50	Multihole*		400	Cu	50/pk.
	CF4MH-100	Multihole*		400	Cu	100/pk.

The Multihole device has a staggered pattern of six features consisting of three circle patterns of 1 micron, 1.4 micron and 2 micron diameter and three ellipse patterns of 1 x 4 microns, 1.4 x 5.6 microns and 2 x 8 microns.

C-flat™ Family of Holey Carbon, Gold Grids for S/TEM and Cryo-TEM (continued)

C-flat™ Holey Carbon Grids for TEM

Thick, Copper Only

Product Code	Cat. #	Hole Size	Hole Spacing	TEM Mesh	TEM Grid	Qty.
CF-1.2/1.3-2C-T	CFT213-50	1.2 µm	1.3 µm	200	Cu	50/pk.
	CFT213-100	1.2 µm	1.3 µm	200	Cu	100/pk.
CF-1.2/1.3-3C-T	CFT313-50	1.2 µm	1.3 µm	300	Cu	50/pk.
	CFT313-100	1.2 µm	1.3 µm	300	Cu	100/pk.
CF-1.2/1.3-4C-T	CFT413-50	1.2 µm	1.3 µm	400	Cu	50/pk.
	CFT413-100	1.2 µm	1.3 µm	400	Cu	100/pk.
CF-2/1-2C-T	CFT212-50	2.0 µm	1.0 µm	200	Cu	50/pk.
	CFT212-100	2.0 µm	1.0 µm	200	Cu	100/pk.
CF-2/1-3C-T	CFT312-50	2.0 µm	1.0 µm	300	Cu	50/pk.
	CFT312-100	2.0 µm	1.0 µm	300	Cu	100/pk.
CF-2/1-4C-T	CFT412-50	2.0 µm	1.0 µm	400	Cu	50/pk.
	CFT412-100	2.0 µm	1.0 µm	400	Cu	100/pk.
CF-2/2-2C-T	CFT-222C-50	2.0 µm	2.0 µm	200	Cu	50/pk.
	CFT-222C-100	2.0 µm	2.0 µm	200	Cu	100/pk.
CF-2/2-3C-T	CFT-223C-50	2.0 µm	2.0 µm	300	Cu	50/pk.
	CFT-223C-100	2.0 µm	2.0 µm	300	Cu	100/pk.
CF-2/2-4C-T	CFT-224C-50	2.0 µm	2.0 µm	400	Cu	50/pk.
	CFT-224C-100	2.0 µm	2.0 µm	400	Cu	100/pk.
CF-2/4-2C-T	CFT242-50	2.0 µm	4.0 µm	200	Cu	50/pk.
	CFT242-100	2.0 µm	4.0 µm	200	Cu	100/pk.
CF-2/4-3C-T	CFT342-50	2.0 µm	4.0 µm	300	Cu	50/pk.
	CFT342-100	2.0 µm	4.0 µm	300	Cu	100/pk.
CF-2/4-4C-T	CFT442-50	2.0 µm	4.0 µm	400	Cu	50/pk.
	CFT442-100	2.0 µm	4.0 µm	400	Cu	100/pk.
CF-4/1-2C-T	CFT241-100	4.0 µm	1.0 µm	200	Cu	100/pk.
CF-4/2-2C-T	CFT422-50	4.0 µm	2.0 µm	200	Cu	50/pk.
	CFT422-100	4.0 µm	2.0 µm	200	Cu	100/pk.
CF-4/2-3C-T	CFT423-50	4.0 µm	2.0 µm	300	Cu	50/pk.
	CFT423-100	4.0 µm	2.0 µm	300	Cu	100/pk.
CF-4/2-4C-T	CFT424-50	4.0 µm	2.0 µm	400	Cu	50/pk.
	CFT424-100	4.0 µm	2.0 µm	400	Cu	100/pk.
CF-MH-2C-T	CFT2MH-50	Multihole*		200	Cu	50/pk.
	CFT2MH-100	Multihole*		200	Cu	100/pk.
CF-MH-3C-T	CFT3MH-50	Multihole*		300	Cu	50/pk.
	CFT3MH-100	Multihole*		300	Cu	100/pk.
CF-MH-4C-T	CFT4MH-50	Multihole*		400	Cu	50/pk.
	CFT4MH-100	Multihole*		400	Cu	100/pk.
CF-1/1-3C-T	CFT31-100	1.0 µm	1.0 µm	300	Cu	100/pk.
CF-1/1-4C-T	CFT41-100	1.0 µm	1.0 µm	400	Cu	100/pk.

The Multihole device has a staggered pattern of six features consisting of three circle patterns of 1 micron, 1.4 micron and 2 micron diameter and three ellipse patterns of 1 x 4 microns, 1.4 x 5.6 microns and 2 x 8 microns.

C-flat™ Holey Carbon Grids for TEM

Gold Only

Product Code	Cat. #	Hole Size	Hole Spacing	TEM Mesh	TEM Grid	Qty.
CF-1.2/1.3-2Au	CF213-50-Au	1.2 µm	1.3 µm	200	Au	50/pk
	CF213-100-Au	1.2 µm	1.3 µm	200	Au	100/pk
CF-1.2/1.3-3Au	CF313-50-Au	1.2 µm	1.3 µm	300	Au	50/pk
	CF313-100-Au	1.2 µm	1.3 µm	300	Au	100/pk
CF-1.2/1.3-4Au	CF413-50-Au	1.2 µm	1.3 µm	400	Au	50/pk
	CF413-100-Au	1.2 µm	1.3 µm	400	Au	100/pk
CF-2/1-2Au	CF212-50-Au	2 µm	1 µm	200	Au	50/pk
	CF212-100-Au	2 µm	1 µm	200	Au	100/pk
CF-2/1-3Au	CF312-50-Au	2 µm	1 µm	300	Au	50/pk
	CF312-100-Au	2 µm	1 µm	300	Au	100/pk
CF-2/1-4Au	CF412-50-Au	2 µm	1 µm	400	Au	50/pk
	CF412-100-Au	2 µm	1 µm	400	Au	100/pk
CF-2/2-2Au	CF222C-50-Au	2 µm	2 µm	200	Au	50/pk
	CF222C-100-Au	2 µm	2 µm	200	Au	100/pk
CF-2/2-3Au	CF223C-50-Au	2 µm	2 µm	300	Au	50/pk
	CF223C-100-Au	2 µm	2 µm	300	Au	100/pk
CF-2/2-4Au	CF224C-50-Au	2 µm	2 µm	400	Au	50/pk
	CF224C-100-Au	2 µm	2 µm	400	Au	100/pk
CF-2/4-2Au	CF242-50-Au	2 µm	4 µm	200	Au	50/pk
	CF242-100-Au	2 µm	4 µm	200	Au	100/pk
CF-2/4-3Au	CF342-50-Au	2 µm	4 µm	300	Au	50/pk
	CF342-100-Au	2 µm	4 µm	300	Au	100/pk
CF-2/4-4Au	CF442-50-Au	2 µm	4 µm	400	Au	50/pk
	CF442-100-Au	2 µm	4 µm	400	Au	100/pk
CF-4/1-4Au	CF441-100-Au	4 µm	1 µm	400	Au	100/pk
CF-4/2-2Au	CF422-50-Au	4 µm	2 µm	200	Au	50/pk
	CF422-100-Au	4 µm	2 µm	200	Au	100/pk
CF-4/2-3Au	CF423-50-Au	4 µm	2 µm	300	Au	50/pk
	CF423-100-Au	4 µm	2 µm	300	Au	100/pk
CF-4/2-4Au	CF424-50-Au	4 µm	2 µm	400	Au	50/pk
	CF424-100-Au	4 µm	2 µm	400	Au	100/pk
CF-MH-2Au	CF2MH-50-Au	Multihole*		200	Au	50/pk
	CF2MH-100-Au	Multihole*		200	Au	100/pk
CF-MH-3Au	CF3MH-50-Au	Multihole*		300	Au	50/pk
	CF3MH-100-Au	Multihole*		300	Au	100/pk
CF-MH-4Au	CF4MH-50-Au	Multihole*		400	Au	50/pk
	CF4MH-100-Au	Multihole*		400	Au	100/pk

C-flat™ Holey Carbon Grids for TEM

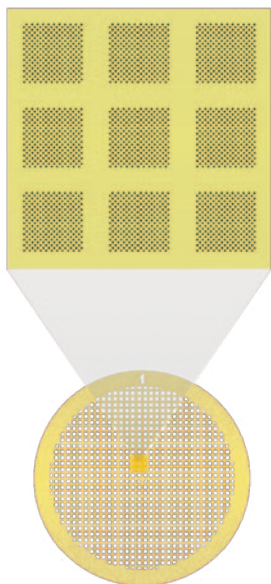
Thick Gold Only

Product Code	Cat. #	Hole Size	Hole Spacing	TEM Mesh	TEM Grid	Qty.
CF-2/4-3Au-T	CFT342-50-Au	2.0 µm	4.0 µm	300	Au	50/pk
	CFT342-100-Au	2.0 µm	4.0 µm	300	Au	100/pk
CF-4/2-3Au-T	CFT423-50-Au	4.0 µm	2.0 µm	300	Au	50/pk
	CFT423-100-Au	4.0 µm	2.0 µm	300	Au	100/pk
CF-MH-3Au-T	CFT3MH-50-Au	Multihole*		300	Au	50/pk
	CFT3MH-100-Au	Multihole*		300	Au	100/pk

The Multihole device has a staggered pattern of six features consisting of three circle patterns of 1 micron, 1.4 micron and 2 micron diameter and three ellipse patterns of 1 x 4 microns, 1.4 x 5.6 microns and 2 x 8 microns.

TEM SUPPORT FILMS

C-flat™ Family of Holey Carbon, Gold Grids for S/TEM and Cryo-TEM (continued)



Specifications

Grid Material	Gold
Mesh Size	200, 300 Mesh
O.D.	3.05mm
Film Material	Gold Alloy
Film Thickness	45nm
Hole Patterns	
<i>0.6/1.0</i>	0.6 um dia., 1.0 μ spacing
<i>1.2/1.3</i>	1.2 um dia., 1.3 μ spacing
<i>2/2</i>	2 um dia., 2 μ spacing

III Au-flat™ for High Resolution Imaging

Gold foil sample supports for Cryo-EM

Au-flat is an ultrastable Cryo-EM sample support with a 45nm holey Gold alloy film on 3 mm gold mesh grids. Au-Flat is a derivative of our patented C-flat product.

What varieties of Au-flat are available?

Au-flat is offered in three configurations:

- 0.6 μm/1.0 μm hole pattern on 300 mesh Gold grids
- 1.2 μm/1.3 μm hole pattern on 300 mesh Gold grids
- 2μm/2μm Hole pattern on 200 mesh Gold grids

What are the benefits of Au-flat over Holey Carbon Supports like C-flat?

Better reconstructions with less data

Au-flat significantly reduces beam-induced motion during imaging compared to carbon films, improving image quality and resolution.

Biocompatible

Au-flat features a holey Au/Pd film on a gold mesh grid, so it's chemically inert and biologically compatible.

Durable

Au-flat's film is significantly stronger than carbon films and is more capable of surviving the Cryo-EM workflow including tweezer handling, glow discharge, blotting, auto-grid loading and plunge freezing.

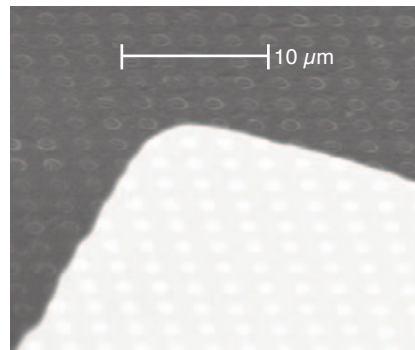
What are the benefits of Au-flat over other Gold Foil TEM Grids?

No Mistakes

The lighter color of the Au/Pd alloy film compared to the underlying gold mesh grid makes it easy to identify the "holey" side of the grid during sample prep. This ensures the sample is deposited on the correct side and that the grid is loaded and imaged in the correct orientation.

Stronger

Au-flat is produced with gold mesh grids that are about 6 microns thicker than typical Cryo-EM grids. This makes the grids stiffer and less likely to bend or deform. The increased thickness is fully compatible with side-entry holders as well as auto-loaders.

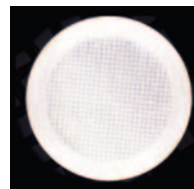


Uniform vitreous ice across the grid

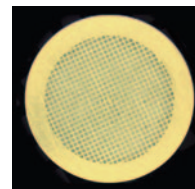
Au-flat uses new, ultra-flat precision gold grids which create a more planar surface.

The result is **more uniform thin ice** across the entire surface, including areas near the grid bars.

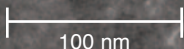
Au/Pd Foil Side



Gold Mesh Side



The lighter color of the Au-Pd film compared to the underlying gold mesh grid makes it easy to identify the film side of the grid during sample preparation.



Ordering Information

Product Code	Cat. #	Hole Size	Hole Spacing	TEM Mesh	TEM Grid	Qty.
GF-0.6/1.0-3Au-45nm-50	AUFT306-50	0.6 μm	1.0 μm	300	Au	50/pk
GF-0.6/1.0-3Au-45nm-5	AUFT306-05	0.6 μm	1.0 μm	300	Au	5/pk
GF-1.2/1.3-3Au-45nm-50	AUFT313-50	1.2 μm	1.3 μm	300	Au	50/pk
GF-1.2/1.3-3Au-45nm-5	AUFT313-05	1.2 μm	1.3 μm	300	Au	5/pk
GF-2/2-2Au-45nm-50	AUFT222-50	2 μm	2 μm	200	Au	50/pk
GF-2/2-2Au-45nm-50	AUFT222-05	2 μm	2 μm	200	Au	5/pk

Accurate defocus

The smaller grain size of the gold film provides more features to focus on, leading to **more accurate defocus** during data collection.

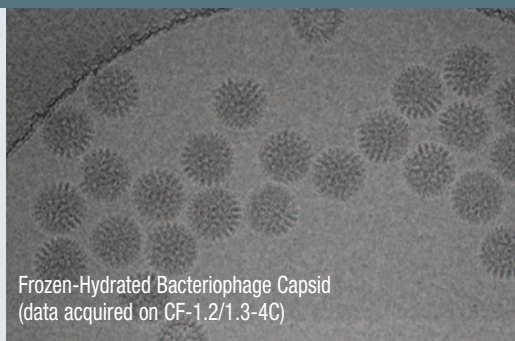
C-flat™ Family of Holey Carbon, Gold Grids for S/TEM and Cryo-TEM (continued)

Holey Carbon Grids for Cryo-TEM

Cryo Preparation Using C-flat™

Overview

C-flat™ is a holey carbon support film, manufactured using a patented semiconductor-based technology without plastics, resists or other soft materials. As a result, the carbon films are flat, uniform and free of residues or plastics. C-flat™ is designed to be an “out of the box” solution, and should require minimal sample preparation. Extensive plasma cleaning is not needed, and could potentially thin the carbon, making it too fragile for blotting or freezing.



Frozen-Hydrated Bacteriophage Capsid
(data acquired on CF-1.2/1.3-4C)

Plasma Preparation

If you are using C-flat™ for the first time, it is recommended that no plasma preparation be used initially. As with any carbon film, plasma preparation is sometimes necessary to make the surface more hydrophilic. If your initial results dictate making the films more hydrophilic, below are some guidelines for preparation using several common systems.

Fischione Model 1020

- 25% Oxygen/75% Argon
- Use 5 grid holder and dampening shield
- Plasma clean grids for 10-30 seconds

Note: It is recommended that the dampening shield be used when cleaning C-flat™ using the Fischione Model 1020 plasma cleaner. The shield will dampen the effect of the plasma, reducing the erosion rate of the carbon while allowing the film to become more hydrophilic.

Gatan Solarus™

- 25% Oxygen/75% Argon
- Place grids on a support (e.g. glass slide)
- Set slide in the bottom of the chamber
- Set RF power to 25 watts
- Plasma clean grids for 10-20 seconds

Glow Discharge

These systems vary widely depending on the manufacturer. Typically, keep the glow from the plasma dim and the clean time approximately 10-30 seconds.

Plunge Freezing

Recommended settings for plunge freezing with the Vitrobot™

- **Temperature:** 4°C
- **Humidity:** 100% (can vary between 90–100%)
- **Blot Time:** 3-5 seconds
- **Volume on Grid:** 3µL (can vary)
- **Drain Time:** 0 seconds
- **Offset:** 0 for regular samples, -1 for viscous

When using the Vitrobot™, it is recommended that the filter paper be changed regularly (generally after freezing 4-5 grids or 10 minutes, whichever comes first.) The filter paper can become saturated in the high humidity environment of the chamber.

Working with Viscous Samples

Generally, lowering the volume of solution on the grid can help to eliminate the need for multiple blots, which can damage the carbon film. As little as 1µL of solution can cover a 3mm grid area if the pipette tip is used to spread the drop, but reducing the volume to 1.5 or 2.0µL will help as well. Once the sample is on the grid, it should be blotted within a few minutes before further evaporation occurs. If a Vitrobot™ is used, changing the offset from 0mm to -1 or -2mm can also help.

Hydrophilicity/Hydrophobicity

Increasing the hydrophilicity of the carbon film will help a droplet spread evenly over the carbon, rather than pool on the surface. The most common method for achieving this is by plasma or glow discharge; recommended settings for various equipment are given. Keep in mind that C-flat™ is manufactured without any plastics or soft materials in the process, therefore plasma or glow discharge steps are only needed to make the surface more hydrophilic, not to clean. For this reason, a lower power and time is generally used.

Adding Carbon to C-flat™

Many C-flat™ parts are now offered in both the standard as well as a thicker carbon film, designed to give each lab the option to choose not only the most appropriate hole geometry and size, but also the ideal carbon thickness for their application. In addition, carbon can be added to C-flat™ either to thicken the existing hole pattern, or as a thin continuous overlay across the hole pattern. Overlays are often used when particles have a strong affinity towards the carbon material.

Keeping the Carbon Intact

C-flat™ is designed to be an “out of the box” solution. Extensive sample preparation steps are generally not required, and often carbon that is torn or broken is a sign of plasma cleaning that is too long and/or at too high a power setting. Please refer to the suggestions on plasma cleaner settings, as well as on working with viscous samples.

YOU MAY NEED...

Plunging Tweezers for the CP3 (Cryoplunge™ 3)



These custom tweezers specifically made to fit the Gatan Cryoplunge™, an instrument used in the preparation of frozen hydrated specimens for cryoEM.

Cat No.	Description	Qty.
CP3690	Plunging Tweezers	each

Vitrobot™ Filter Paper

This special Filter Paper has an outer diameter of 55 mm, with an inner diameter of 20 mm. Made from Grade 595 paper.



Cat No.	Description	Qty.
71166-65	Vitrobot™ Filter Paper	100/pk

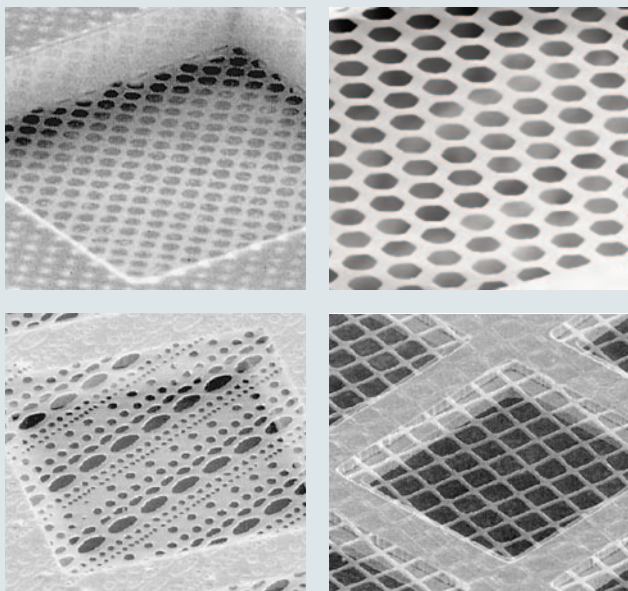
TEM SUPPORT FILMS

QUANTIFOIL® Holey Carbon Films

Overview

QUANTIFOIL® is a perforated support foil with pre-defined hole size, shape and arrangement. It has advantages in electron microscopy (EM) or low-energy electron point source (LEEPS) microscopy when compared with conventional holey film.

QUANTIFOIL® is offered with circular and square, orthogonal arranged holes. Films with different hole sizes and bar widths are available. Carbon is the standard material that makes the foil.



QUANTIFOIL® is a superior quality of holey carbon film, which facilitates the use of automation in TEM. (e.g. The National Resource for Automated Molecular Microscopy, at the Scripps Research Institute, has developed a system, called Legimon, for automatically acquiring images from a transmission electron microscope).

The surface properties of QUANTIFOIL® holey carbon support film, especially the wetting properties, may have to be adapted according to one's particular requirements. Untreated aging QUANTIFOIL® tends to be hydrophobic. Hydrophilicity of the foil can be achieved by glow discharging in residual air or by metal coating.

QUANTIFOIL® in low-energy electron point source (LEEPS) microscopy. QUANTIFOIL® with a regular pattern is required in order to be able to distinguish an object, which is spanned over a hole. An object cannot be discriminated from the support in the case of conventional holey support film. (H.W. Fink & C. Schonberger, University of Basel, used QUANTIFOIL® for the measurement of electrical current through DNA molecules.)

The foil is ~12 nm thick and mounted on either copper, nickel or gold grids with either square or round holes of different sizes.

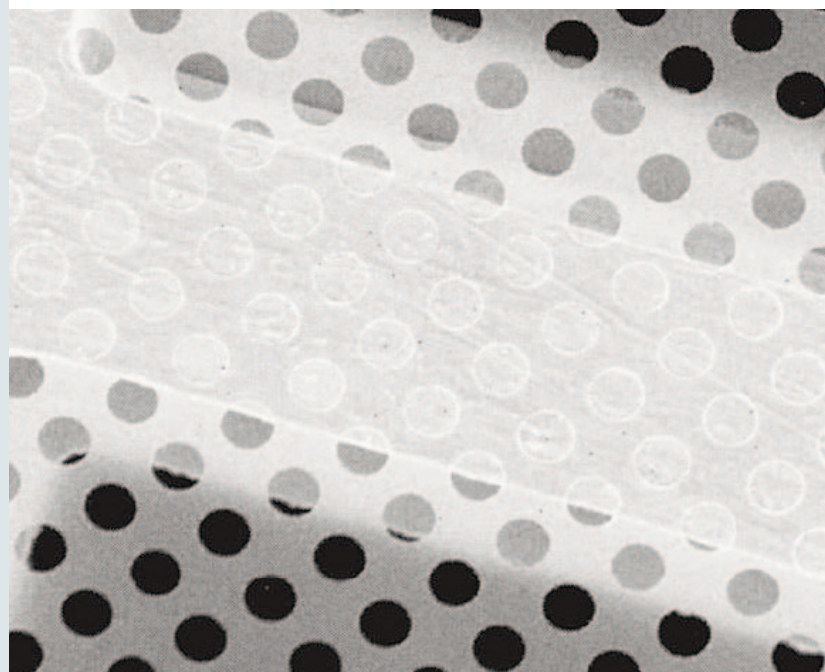
Holey films with 2µ round holes are used at magnifications between 30,000x and 40,000x.

QUANTIFOIL® with Circular Holes

QUANTIFOIL® with circular holes is used in cryoelectron tomographic reconstruction. The roundness of the holes is advantageous with respect to the formation of an ice layer of constant thickness. The hole size chosen depends on the magnification used, and on whether or not one wishes to include support film in the image.

Assessment of the image quality is easier when foil is included in the picture, because the power spectrum of a foil is stronger than that of unsupported ice.

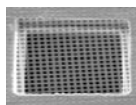
QUANTIFOIL® type	Hole size in µm	Spacing in µm	Period in µm
R 0.6/1	0.6	1.0	1.6
R 1/2	1.0	2.0	3.0
R 1/4	1.0	4.0	5.0
R 1.2/1.3	1.2	1.3	2.5
R 1.2/20	1.2	20.0	21.2
R 2/1	2.0	1.0	3.0
R 2/2	2.0	2.0	4.0
R 2/4	2.0	4.0	6.0
R 3/3	3.0	3.0	6.0
R 3/5	3.0	5.0	8.0
R 3.5/1	3.5	1.0	4.5
R 5/10	5.0	10.0	15.0
R 5/20	5.0	20.0	25.0
R 6/6.5	6.0	6.5	12.5
R 6/100	6.0	100.0	106.0
R 10/5	10.0	5.0	15.0
R 10/10	10.0	10.0	20.0
R 10/20	10.0	20.0	30.0
R 17/5	17.5	5.0	22.5



QUANTIFOIL® Holey Carbon Films (continued)

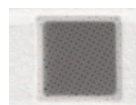
III QUANTIFOIL® with Circular Holes (continued)

QUANTIFOIL® R 0.6/1 Hole size is 0.6µ. Space between holes is 1µ. Center to center is 1.6µ (hole size may be as large as 1µ).



Grid Type	Hole Size	Period	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	0.6µm	1.6µm	Q210CR-06	Q310CR-06	Q410CR-06	10/pk
			Q220CR-06	Q320CR-06	Q420CR-06	25/pk
			Q225CR-06	Q325CR-06	Q425CR-06	50/pk
			Q250CR-06	Q350CR-06	Q450CR-06	100/pk
Nickel	0.6µm	1.6µm	Q210NR-06	Q310NR-06	Q410NR-06	10/pk
			Q220NR-06	Q320NR-06	Q420NR-06	25/pk
			Q225NR-06	Q325NR-06	Q425NR-06	50/pk
			Q250NR-06	Q350NR-06	Q450NR-06	100/pk
Gold	0.6µm	1.6µm	Q210AR-06	Q310AR-06	Q410AR-06	10/pk
			Q220AR-06	Q320AR-06	Q420AR-06	25/pk
			Q225AR-06	Q325AR-06	Q425AR-06	50/pk
			Q250AR-06	Q350AR-06	Q450AR-06	100/pk

QUANTIFOIL® R 1/2 Hole size is 1µ. Space between holes is 2µ. Center to center is 3µ



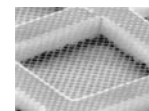
Grid Type	Hole Size	Period	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	1µm	3µm	Q210CR-12	Q310CR-12	Q410CR-12	10/pk
			Q225CR-12	Q325CR-12	Q425CR-12	25/pk
			Q250CR-12	Q350CR-12	Q450CR-12	50/pk
			Q2100CR-12	Q3100CR-12	Q4100CR-12	100/pk
Nickel	1µm	3µm	Q210NR-12	Q310NR-12	Q410NR-12	10/pk
			Q225NR-12	Q325NR-12	Q425NR-12	25/pk
			Q250NR-12	Q350NR-12	Q450NR-12	50/pk
			Q2100NR-12	Q3100NR-12	Q4100NR-12	100/pk
Gold	1µm	3µm	Q210AR-12	Q310AR-12	Q410AR-12	10/pk
			Q225AR-12	Q325AR-12	Q425AR-12	25/pk
			Q250AR-12	Q350AR-12	Q450AR-12	50/pk
			Q2100AR-12	Q3100AR-12	Q4100AR-12	100/pk

QUANTIFOIL® R 1/4 may be preferred over R 1.2/1.3, when an increased tolerance with respect to the position of beam, and a larger beam diameter are desired, such as in the case of automated image acquisition.



Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CR-14	Q310CR-14	Q410CR-14	10/pk
	Q220CR-14	Q320CR-14	Q420CR-14	25/pk
	Q225CR-14	Q325CR-14	Q425CR-14	50/pk
	Q250CR-14	Q350CR-14	Q450CR-14	100/pk
Nickel	Q210NR-14	Q310NR-14	Q410NR-14	10/pk
	Q220NR-14	Q320NR-14	Q420NR-14	25/pk
	Q225NR-14	Q325NR-14	Q425NR-14	50/pk
	Q250NR-14	Q350NR-14	Q450NR-14	100/pk
Gold	Q210AR-14	Q310AR-14	Q410AR-14	10/pk
	Q220AR-14	Q320AR-14	Q420AR-14	25/pk
	Q225AR-14	Q325AR-14	Q425AR-14	50/pk
	Q250AR-14	Q350AR-14	Q450AR-14	100/pk

QUANTIFOIL® R 1.2/1.3 A foil with ~1.2 µm circular holes and a spacing of ~1.3µm between the holes. This type is used at magnifications around 50,000x.



Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CR1.3	Q310CR1.3	Q410CR1.3	10/pk
	Q225-CR1.3	Q325CR1.3	Q425CR1.3	25/pk
	Q250-CR1.3	Q350CR1.3	Q450CR1.3	50/pk
	Q2100CR1.3	Q3100CR1.3	Q4100CR1.3	100/pk
Nickel	Q210NR1.3	Q310NR1.3	Q410NR1.3	10/pk
	Q225NR-1.3	Q325NR1.3	Q425NR1.3	25/pk
	Q250-NI1.3	Q350NR1.3	Q450NR1.3	50/pk
	Q2100NR1.3	Q3100NR1.3	Q4100NR1.3	100/pk
Gold	Q210AR1.3	Q310AR1.3	Q410AR1.3	10/pk
	Q225AR1.3	Q325AR1.3	Q425AR1.3	25/pk
	Q250AR1.3	Q350AR1.3	Q450AR1.3	50/pk
	Q2100AR1.3	Q3100AR1.3	Q4100AR1.3	100/pk

QUANTIFOIL® R 1.2/1.3 with Ultrathin Carbon

Copper	Q210CR1.3-2nm	Q310CR1.3-2nm	Q410CR1.3-2nm	10/pk
	Q225CR1.3-2nm	Q325CR1.3-2nm	Q425CR1.3-2nm	25/pk
	Q250CR1.3-2nm	Q350CR1.3-2nm	Q450CR1.3-2nm	50/pk
	Q2100CR1.3-2nm	Q3100CR1.3-2nm	Q4100CR1.3-2nm	100/pk
Gold	Q210AR1.3-2nm	Q310AR1.3-2nm	Q410AR1.3-2nm	10/pk
	Q225AR1.3-2nm	Q325AR1.3-2nm	Q425AR1.3-2nm	25/pk
	Q250AR1.3-2nm	Q350AR1.3-2nm	Q450AR1.3-2nm	50/pk
	Q2100AR1.3-2nm	Q3100AR1.3-2nm	Q4100AR1.3-2nm	100/pk

QUANTIFOIL® R 1.2/20 Hole size is 1.2µ. Space between holes is 20µ. Center to center is 21.2µ.

Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CR21.2	Q310CR21.2	Q410CR21.2	10/pk
	Q225CR21.2	Q325CR21.2	Q425CR21.2	25/pk
	Q250CR21.2	Q350CR21.2	Q450CR21.2	50/pk
	Q2100CR21.2	Q3100CR21.2	Q4100CR21.2	100/pk
Nickel	Q210NR21.2	Q310NR21.2	Q410NR21.2	10/pk
	Q225NR21.2	Q325NR21.2	Q425NR21.2	25/pk
	Q250NR21.2	Q350NR21.2	Q450NR21.2	50/pk
	Q2100NR21.2	Q3100NR21.2	Q4100NR21.2	100/pk
Gold	Q210AR21.2	Q310AR21.2	Q410AR21.2	10/pk
	Q225AR21.2	Q325AR21.2	Q425AR21.2	25/pk
	Q250AR21.2	Q350AR21.2	Q450AR21.2	50/pk
	Q2100AR21.2	Q3100AR21.2	Q4100AR21.2	100/pk

TECHNICAL TIP

Removing a Charge from the Surface of Grids

Sometimes when you are trying to pick up sections, they won't adhere to the grid surface. If you don't have time to glow discharge clean the grid surfaces, try this little trick. Dip the grids in distilled water for a moment and wick off the excess with filter paper. Let them dry while you are arranging your sections. Your sections should now adhere to the grid surface. Some labs soak the grids they will use for the day in distilled water until they are needed. If this procedure fails, reclean your grids with acetone or chloroform or glow discharge clean the grid surfaces.

Jeanette Killius, NEOUCOM, Rootstown, OH.

TEM SUPPORT FILMS

QUANTIFOIL® Holey Carbon Films (continued)

TECHNICAL TIP

Additional Ultrathin Continuous Carbon Layer

An ultrathin (2-3 nm) carbon layer applied to grids is widely recommended to improve particle distribution^{1,2,3} and has been shown to improve data quality when applied to both QUANTIFOIL®⁴ Holey Carbon Films and UltraAuFoil®⁵ Gold Supports.

Many biomolecules have a strong affinity for carbon, and a number of factors contribute to the improved specimen quality:

- Increased numbers of particles due to adsorption of biomolecules onto carbon prior to blotting.
- Improved particle distribution due to interaction with carbon surface across the hole.
- Reduction in the number of particles adopting a preferred orientation.

An additional carbon layer can be added to most QUANTIFOIL holey carbon film support. The most popular thickness is 2 nm.



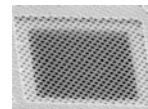
Shown above is the structure of *Photorhabdus luminescens* TcdA1, a large multi-subunit complex toxin, with activity against insects, whose structure was determined using images collected on QUANTIFOIL R 2/1 grids with a 2 nm additional carbon layer⁶.

References

1. Passmore, LA and Russo, CJ. *Methods Enzymol.* 579: 51-86 (2016).
2. Drulyte, I et al. *Acta Cryst D*74: 560-571 (2018).
3. Thompson, RF et al. *Methods* 100: 3-15 (2016).
4. Rawson, S et al. *Structure* 23: 461-471 (2015).
5. Russo, CJ and Passmore, LA. *J. Struct. Biol.* 193:33-44 (2016).
6. Leidreiter, F et al. *Sci. Adv.* 5: eaax6497 (2019).

III QUANTIFOIL® with Circular Holes (continued)

QUANTIFOIL® R 2/1 has more open area than R 2/2. It is used when focusing is carried out on the edge of a hole burnt in the ice in a neighboring hole instead of on the foil adjacent to the hole.

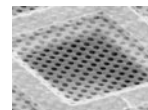


Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CR1	Q310CR1	Q410CR1	10/pk
Hole Size: 1µm	Q225CR1	Q325CR1	Q425CR1	25/pk
Period: 3µm	Q250CR1	Q350CR1	Q450CR1	50/pk
	Q2100CR1	Q3100CR1	Q4100CR1	100/pk
Nickel	Q210NR1	Q310NR1	Q410NR1	10/pk
Hole Size: 1µm	Q225NR1	Q325NR1	Q425NR1	25/pk
Period: 3µm	Q250NR1	Q350NR1	Q450NR1	50/pk
	Q2100NR1	Q3100NR1	Q4100NR1	100/pk
Gold	Q210AR1	Q310AR1	Q410AR1	10/pk
Hole Size: 1µm	Q225-AR1	Q325AR1	Q425AR1	25/pk
Period: 3µm	Q250-AR1	Q350AR1	Q450AR1	50/pk
	Q2100AR1	Q3100AR1	Q4100AR1	100/pk

QUANTIFOIL® R 2/1 with Ultrathin Carbon

Copper	Q210CR1-2nm	Q310CR1-2nm	Q410CR1-2nm	10/pk
Hole Size: 1µm	Q225CR1-2nm	Q325CR1-2nm	Q425CR1-2nm	25/pk
Period: 3µm	Q250CR1-2nm	Q350CR1-2nm	Q450CR1-2nm	50/pk
	Q2100CR1-2nm	Q3100CR1-2nm	Q4100CR13-2nm	100/pk
Gold	Q210AR1-2nm	Q310AR1-2nm	Q410AR1-2nm	10/pk
Hole Size: 1µm	Q225AR1-2nm	Q325AR1-2nm	Q425AR1-2nm	25/pk
Period: 3µm	Q250AR1-2nm	Q350AR1-2nm	Q450AR1-2nm	50/pk
	Q2100AR1-2nm	Q3100AR1-2nm	Q4100AR1-2nm	100/pk

QUANTIFOIL® R 2/2 Holey films with 2 µm circular holes are used at magnifications between 30,000x and 40,000x.



Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CR2	Q310CR2	Q410CR2	10/pk
Hole Size: 2µm	Q225-CR2	Q325CR2	Q425CR2	25/pk
Period: 4µm	Q250-CR2	Q350CR2	Q450CR2	50/pk
	Q2100CR2	Q3100CR2	Q4100CR2	100/pk
Nickel	Q210NR2	Q310NR2	Q410NR2	10/pk
Hole Size: 2µm	Q225-NR2	Q325NR2	Q425NR2	25/pk
Period: 4µm	Q250-NR2	Q350NR2	Q450NR2	50/pk
	Q2100NR2	Q3100NR2	Q4100NR2	100/pk
Gold	Q210AR2	Q310AR2	Q410AR2	10/pk
Hole Size: 2µm	Q225-AR2	Q325AR2	Q425AR2	25/pk
Period: 4µm	Q250-AR2	Q350AR2	Q450AR2	50/pk
	Q2100AR2	Q3100AR2	Q4100AR2	100/pk

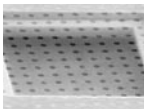
QUANTIFOIL® R 2/2 with Ultrathin Carbon

Copper	Q210CR2-2nm	Q310CR2-2nm	Q410CR2-2nm	10/pk
Hole Size: 2µm	Q225CR2-2nm	Q325CR2-2nm	Q425CR2-2nm	25/pk
Period: 4µm	Q250CR2-2nm	Q350CR2-2nm	Q450CR2-2nm	50/pk
	Q2100CR2-2nm	Q3100CR2-2nm	Q4100CR2-2nm	100/pk
Gold	Q210AR2-2nm	Q310AR2-2nm	Q410AR2-2nm	10/pk
Hole Size: 2µm	Q225AR2-2nm	Q325AR2-2nm	Q425AR2-2nm	25/pk
Period: 4µm	Q250AR2-2nm	Q350AR2-2nm	Q450AR2-2nm	50/pk
	Q2100AR2-2nm	Q3100AR2-2nm	Q4100AR2-2nm	100/pk

QUANTIFOIL® Holey Carbon Films (continued)

QUANTIFOIL® with Circular Holes (continued)

QUANTIFOIL® R 2/4 may be preferred over R 2/2, when an increased tolerance with respect to the position of beam, and a larger beam diameter are desired, such as in the case of automated image acquisition.

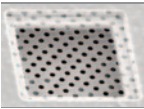


Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CR-4	Q310CR-4	Q410CR-4	10/pk
Hole Size: 2µm	Q225-CR4	Q325CR-4	Q425CR-4	25/pk
Period: 6µm	Q250-CR4	Q350CR-4	Q450CR-4	50/pk
	Q2100CR-4	Q3100CR-4	Q4100CR-4	100/pk
Nickel	Q210NR-4	Q310NR-4	Q410NR-4	10/pk
Hole Size: 2µm	Q225-NR4	Q325NR-4	Q425NR-4	25/pk
Period: 6µm	Q250-NR4	Q350NR-4	Q450NR-4	50/pk
	Q2100NR-4	Q3100NR-4	Q4100NR-4	100/pk
Gold	Q210AR-4	Q310AR-4	Q410AR-4	10/pk
Hole Size: 2µm	Q225-AR4	Q325AR-4	Q425AR-4	25/pk
Period: 6µm	Q250-AR4	Q350AR-4	Q450AR-4	50/pk
	Q2100AR-4	Q3100AR-4	Q4100AR-4	100/pk

QUANTIFOIL® R 2/4 with Ultrathin Carbon

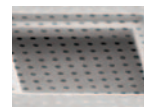
Copper	Q210CR-4-2nm	Q310CR-4-2nm	Q410CR-4-2nm	10/pk
Hole Size: 2µm	Q225CR4-2nm	Q325CR-4-2nm	Q425CR-4-2nm	25/pk
Period: 6µm	Q250CR4-2nm	Q350CR-4-2nm	Q450CR-4-2nm	50/pk
	Q2100CR4-2nm	Q3100CR-4-2nm	Q4100CR-4-2nm	100/pk
Gold	Q210AR-4-2nm	Q310AR-4-2nm	Q410AR-4-2nm	10/pk
Hole Size: 2µm	Q225AR4-2nm	Q325AR-4-2nm	Q425AR-4-2nm	25/pk
Period: 6µm	Q250AR4-2nm	Q350AR-4-2nm	Q450AR-4-2nm	50/pk
	Q2100AR-4-2nm	Q3100AR-4-2nm	Q4100AR-4-2nm	100/pk

QUANTIFOIL® R 3/3 Hole size is 3µ. Space between holes is 3µ. Center to center is 6µ.



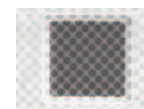
Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CR3	Q310CR3	Q410CR3	10/pk
Hole Size: 3µm	Q225CR3	Q325CR3	Q425CR3	25/pk
Period: 6µm	Q250CR3	Q350CR3	Q450CR3	50/pk
	Q2100CR3	Q3100CR3	Q4100CR3	100/pk
Nickel	Q210NR3	Q310NR3	Q410NR3	10/pk
Hole Size: 3µm	Q225NR3	Q325NR3	Q425NR3	25/pk
Period: 6µm	Q250NR3	Q350NR3	Q450NR3	50/pk
	Q2100NR3	Q3100NR3	Q4100NR3	100/pk
Gold	Q210AR3	Q310AR3	Q410AR3	10/pk
Hole Size: 3µm	Q225AR3	Q325AR3	Q425AR3	25/pk
Period: 6µm	Q250AR3	Q350AR3	Q450AR3	50/pk
	Q2100AR3	Q3100AR3	Q4100AR3	100/pk

QUANTIFOIL® R 3/5 Hole size is 3µ. Space between holes is 5µ. Center to center is 8µ.



Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CR5	Q310CR5	Q410CR5	10/pk
Hole Size: 3µm	Q225CR5	Q325CR5	Q425CR5	25/pk
Period: 8µm	Q250CR5	Q350CR5	Q450CR5	50/pk
	Q2100CR5	Q3100CR5	Q4100CR5	100/pk
Nickel	Q210NR5	Q310NR5	Q410NR5	10/pk
Hole Size: 3µm	Q225NR5	Q325NR5	Q425NR5	25/pk
Period: 8µm	Q250NR5	Q350NR5	Q450NR5	50/pk
	Q2100NR5	Q3100NR5	Q4100NR5	100/pk
Gold	Q210AR5	Q310AR5	Q410AR5	10/pk
Hole Size: 3µm	Q225AR5	Q325AR5	Q425AR5	25/pk
Period: 8µm	Q250AR5	Q350AR5	Q450AR5	50/pk
	Q2100AR5	Q3100AR5	Q4100AR5	100/pk

QUANTIFOIL® R 3.5/1 may be preferred over foils with smaller holes if the carbon film should be outside the frame of the image. This option can be desirable in the case of extended objects, such as filamentous objects, for example.



Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CR-35	Q310CR-35	Q410CR-35	10/pk
Hole Size: 3.5µm	Q220CR-35	Q320CR-35	Q420CR-35	25/pk
Period: 4.5µm	Q225CR-35	Q325CR-35	Q425CR-35	50/pk
	Q250CR-35	Q350CR-35	Q450CR-35	100/pk
Nickel	Q210NR-35	Q310NR-35	Q410NR-35	10/pk
Hole Size: 3.5µm	Q220NR-35	Q320NR-35	Q420NR-35	25/pk
Period: 4.5µm	Q225NR-35	Q325NR-35	Q425NR-35	50/pk
	Q250NR-35	Q350NR-35	Q450NR-35	100/pk
Gold	Q210AR-35	Q310AR-35	Q410AR-35	10/pk
Hole Size: 3.5µm	Q220AR-35	Q320AR-35	Q420AR-35	25/pk
Period: 4.5µm	Q225AR-35	Q325AR-35	Q425AR-35	50/pk
	Q250AR-35	Q350AR-35	Q450AR-35	100/pk

QUANTIFOIL® R 5/10 Hole size is 5µ. Space between holes is 10µ. Center to center is 15µ.



Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CR510	Q310CR510	Q410CR510	10/pk
Hole Size: 5µm	Q225CR510	Q325CR510	Q425CR510	25/pk
Period: 15µm	Q250CR510	Q350CR510	Q450CR510	50/pk
	Q2100CR510	Q3100CR510	Q4100CR510	100/pk
Nickel	Q210NR510	Q310NR510	Q410NR510	10/pk
Hole Size: 5µm	Q225NR510	Q325NR510	Q425NR510	25/pk
Period: 15µm	Q250NR510	Q350NR510	Q450NR510	50/pk
	Q2100NR510	Q3100NR510	Q4100NR510	100/pk
Gold	Q210AR510	Q310AR510	Q410AR510	10/pk
Hole Size: 5µm	Q225AR510	Q325AR510	Q425AR510	25/pk
Period: 15µm	Q250AR510	Q350AR510	Q450AR510	50/pk
	Q2100AR510	Q3100AR510	Q4100AR510	100/pk

QUANTIFOIL® R 5/20 Hole size is 5µ. Space between holes is 20µ. Center to center is 25µ.



Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CR-520	Q310CR-520	Q410CR-520	10/pk
Hole Size: 5µm	Q220CR-520	Q320CR-520	Q420CR-520	25/pk
Period: 25µm	Q225CR-520	Q325CR-520	Q425CR-520	50/pk
	Q250CR-520	Q350CR-520	Q450CR-520	100/pk
Nickel	Q210NR-520	Q310NR-520	Q410NR-520	10/pk
Hole Size: 5µm	Q220NR-520	Q320NR-520	Q420NR-520	25/pk
Period: 25µm	Q225NR-520	Q325NR-520	Q425NR-520	50/pk
	Q250NR-520	Q350NR-520	Q450NR-520	100/pk
Gold	Q210AR-520	Q310AR-520	Q410AR-520	10/pk
Hole Size: 5µm	Q220AR-520	Q320AR-520	Q420AR-520	25/pk
Period: 25µm	Q225AR-520	Q325AR-520	Q425AR-520	50/pk
	Q250AR-520	Q350AR-520	Q450AR-520	100/pk

TEM SUPPORT FILMS

QUANTIFOIL® Holey Carbon Films (continued)

III QUANTIFOIL® with Circular Holes (continued)

QUANTIFOIL® R 6/6.5 Hole size is 6 μ . Space between holes is 6.5 μ . Center to center is 12.5 μ



Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper Hole Size: 6 μ m Period: 12.5 μ m	Q210CR665	Q310CR665	Q410CR665	10/pk
	Q225CR665	Q325CR665	Q425CR665	25/pk
	Q250CR665	Q350CR665	Q450CR665	50/pk
	Q2100CR665	Q3100CR665	Q4100CR665	100/pk
Nickel Hole Size: 6 μ m Period: 12.5 μ m	Q210NR665	Q310NR665	Q410NR665	10/pk
	Q225NR665	Q325NR665	Q425NR665	25/pk
	Q250NR665	Q350NR665	Q450NR665	50/pk
	Q2100NR665	Q3100NR665	Q4100NR665	100/pk
Gold Hole Size: 6 μ m Period: 12.5 μ m	Q210AR665	Q310AR665	Q410AR665	10/pk
	Q225AR665	Q325AR665	Q425AR665	25/pk
	Q250AR665	Q350AR665	Q450AR665	50/pk
	Q2100AR665	Q3100AR665	Q4100AR665	100/pk

QUANTIFOIL® R 10/10 Hole size is 10 μ . Space between holes is 10 μ . Center to center is 20 μ

Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper Hole Size: 10 μ m Period: 20 μ m	Q210CR1010	Q310CR1010	Q410CR1010	10/pk
	Q225CR1010	Q325CR1010	Q425CR1010	25/pk
	Q250CR1010	Q350CR1010	Q450CR1010	50/pk
	Q2100CR1010	Q3100CR1010	Q4100CR1010	100/pk
Nickel Hole Size: 10 μ m Period: 20 μ m	Q210NR1010	Q310NR1010	Q410NR1010	10/pk
	Q225NR1010	Q325NR1010	Q425NR1010	25/pk
	Q250NR1010	Q350NR1010	Q450NR1010	50/pk
	Q2100NR1010	Q3100NR1010	Q4100NR1010	100/pk
Gold Hole Size: 10 μ m Period: 20 μ m	Q210AR1010	Q310AR1010	Q410AR1010	10/pk
	Q225AR1010	Q325AR1010	Q425AR1010	25/pk
	Q250AR1010	Q350AR1010	Q450AR1010	50/pk
	Q2100AR1010	Q3100AR1010	Q4100AR1010	100/pk

QUANTIFOIL® R 6/100 Hole size is 6 μ . Space between holes is 100 μ . Center to center is 106 μ

Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper Hole Size: 6 μ m Period: 106 μ m	Q210CR6100	Q310CR6100	Q410CR6100	10/pk
	Q225CR6100	Q325CR6100	Q425CR6100	25/pk
	Q250CR6100	Q350CR6100	Q450CR6100	50/pk
	Q2100CR6100	Q3100CR6100	Q4100CR6100	100/pk
Nickel Hole Size: 6 μ m Period: 106 μ m	Q210NR6100	Q310NR6100	Q410NR6100	10/pk
	Q225NR6100	Q325NR6100	Q425NR6100	25/pk
	Q250NR6100	Q350NR6100	Q450NR6100	50/pk
	Q2100NR6100	Q3100NR6100	Q4100NR6100	100/pk
Gold Hole Size: 6 μ m Period: 106 μ m	Q210AR6100	Q310AR6100	Q410AR6100	10/pk
	Q225AR6100	Q325AR6100	Q425AR6100	25/pk
	Q250AR6100	Q350AR6100	Q450AR6100	50/pk
	Q2100AR6100	Q3100AR6100	Q4100AR6100	100/pk

QUANTIFOIL® R 10/20 Hole size is 10 μ . Space between holes is 20 μ . Center to center is 30 μ

Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper Hole Size: 10 μ m Period: 30 μ m	Q210CR1020	Q310CR1020	Q410CR1020	10/pk
	Q225CR1020	Q325CR1020	Q425CR1020	25/pk
	Q250CR1020	Q350CR1020	Q450CR1020	50/pk
	Q2100CR1020	Q3100CR1020	Q4100CR1020	100/pk
Nickel Hole Size: 10 μ m Period: 30 μ m	Q210NR1020	Q310NR1020	Q410NR1020	10/pk
	Q225NR1020	Q325NR1020	Q425NR1020	25/pk
	Q250NR1020	Q350NR1020	Q450NR1020	50/pk
	Q2100NR1020	Q3100NR1020	Q4100NR1020	100/pk
Gold Hole Size: 10 μ m Period: 30 μ m	Q210AR1020	Q310AR1020	Q410AR1020	10/pk
	Q225AR1020	Q325AR1020	Q425AR1020	25/pk
	Q250AR1020	Q350AR1020	Q450AR1020	50/pk
	Q2100AR1020	Q3100AR1020	Q4100AR1020	100/pk

QUANTIFOIL® R 10/5
Hole size is 10 μ . Space between holes is 5 μ . Center to center is 15 μ



Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper Hole Size: 10 μ m Period: 15 μ m	Q210CR105	Q310CR105	Q410CR105	10/pk
	Q225CR105	Q325CR105	Q425CR105	25/pk
	Q250CR105	Q350CR105	Q450CR105	50/pk
	Q2100CR105	Q3100CR105	Q4100CR105	100/pk
Nickel Hole Size: 10 μ m Period: 15 μ m	Q210NR105	Q310NR105	Q410NR105	10/pk
	Q225NR105	Q325NR105	Q425NR105	25/pk
	Q250NR105	Q350NR105	Q450NR105	50/pk
	Q2100NR105	Q3100NR105	Q4100NR105	100/pk
Gold Hole Size: 10 μ m Period: 15 μ m	Q210AR105	Q310AR105	Q410AR105	10/pk
	Q225AR105	Q325AR105	Q425AR105	25/pk
	Q250AR105	Q350AR105	Q450AR105	50/pk
	Q2100AR105	Q3100AR105	Q4100AR105	100/pk

QUANTIFOIL® R 17/5 Hole size is 17.5 μ . Space between holes is 5 μ . Center to center is 22.5 μ

Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper Hole Size: 17.5 μ m Period: 22.5 μ m	Q210CR175	Q310CR175	Q410CR175	10/pk
	Q225CR175	Q325CR175	Q425CR175	25/pk
	Q250CR175	Q350CR175	Q450CR175	50/pk
	Q2100CR175	Q3100CR175	Q4100CR175	100/pk
Nickel Hole Size: 17.5 μ m Period: 22.5 μ m	Q210NR175	Q310NR175	Q410NR175	10/pk
	Q225NR175	Q325NR175	Q425NR175	25/pk
	Q250NR175	Q350NR175	Q450NR175	50/pk
	Q2100NR175	Q3100NR175	Q4100NR175	100/pk
Gold Hole Size: 17.5 μ m Period: 22.5 μ m	Q210AR175	Q310AR175	Q410AR175	10/pk
	Q225AR175	Q325AR175	Q425AR175	25/pk
	Q250AR175	Q350AR175	Q450AR175	50/pk
	Q2100AR175	Q3100AR175	Q4100AR175	100/pk

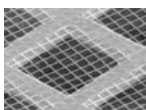
QUANTIFOIL® Holey Carbon Films (continued)

III QUANTIFOIL® with Square Holes

QUANTIFOIL® with square holes and relatively narrow bars can be used in EM to support a thin carbon film, which by itself is too fragile to span a grid square. Alternatively, this holey film can directly support an object larger than the holes.

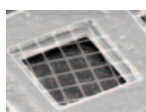
QUANTIFOIL® type	Hole size in µm	Spacing in µm	Period in µm
S 7/2	7	2.0	9
S 35/5	35	5	40
S 35/10	35	10	45

QUANTIFOIL® S 7/2 constitutes an optimum between a maximum of open area on the one hand, and mechanical stability on the other hand.



Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CS7	Q310CS7	Q410CS7	10/pk
Hole Size: 7x7µm	Q225-CS7	Q325CS7	Q425CS7	25/pk
Period: 9µm	Q250-CS7	Q350CS7	Q450CS7	50/pk
	Q2100CS7	Q3100CS7	Q4100CS7	100/pk
Nickel	Q210NS7	Q310NS7	Q410NS7	10/pk
Hole Size: 7x7µm	Q225-NS7	Q325NS7	Q425NS7	25/pk
Period: 9µm	Q250-NS7	Q350NS7	Q450NS7	50/pk
	Q2100NS7	Q3100NS7	Q4100NS7	100/pk
Gold	Q210AS7	Q310AS7	Q410AS7	10/pk
Hole Size: 7x7µm	Q225-AS7	Q325AS7	Q425AS7	25/pk
Period: 9µm	Q250-AS7	Q350AS7	Q450AS7	50/pk
	Q2100AS7	Q3100AS7	Q4100AS7	100/pk

QUANTIFOIL® S 35/5 Hole size is 35µ. Space between holes is 5µ. Center to center is 40µ.



Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CS355	Q310CS355	Q410CS355	10/pk
Hole Size: 35x35µm	Q225CS355	Q325CS355	Q425CS355	25/pk
Period: 40µm	Q250CS355	Q350CS355	Q450CS355	50/pk
	Q2100CS355	Q3100CS355	Q4100CS355	100/pk
Nickel	Q210NS355	Q310NS355	Q410NS355	10/pk
Hole Size: 35x35µm	Q225NS355	Q325NS355	Q425NS355	25/pk
Period: 40µm	Q250NS355	Q350NS355	Q450NS355	50/pk
	Q2100NS355	Q3100NS355	Q4100NS355	100/pk
Gold	Q210AS355	Q310AS355	Q410AS355	10/pk
Hole Size: 35x35µm	Q225AS355	Q325AS355	Q425AS355	25/pk
Period: 40µm	Q250AS355	Q350AS355	Q450AS355	50/pk
	Q2100AS355	Q3100AS355	Q4100AS355	100/pk

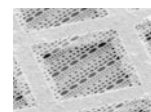
QUANTIFOIL® S 35/10 Hole size is 35µ. Space between holes is 10µ. Center to center is 45µ.



Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CS3510	Q310CS3510	Q410CS3510	10/pk
Hole Size: 35x35µm	Q225CS3510	Q325CS3510	Q425CS3510	25/pk
Period: 45µm	Q250CS3510	Q350CS3510	Q450CS3510	50/pk
	Q2100CS3510	Q3100CS3510	Q4100CS3510	100/pk
Nickel	Q210NS3510	Q310NS3510	Q410NS3510	10/pk
Hole Size: 35x35µm	Q225NS3510	Q325NS3510	Q425NS3510	25/pk
Period: 45µm	Q250NS3510	Q350NS3510	Q450NS3510	50/pk
	Q2100NS3510	Q3100NS3510	Q4100NS3510	100/pk
Gold	Q210AS3510	Q310AS3510	Q410AS3510	10/pk
Hole Size: 35x35µm	Q225AS3510	Q325AS3510	Q425AS3510	25/pk
Period: 45µm	Q250AS3510	Q350AS3510	Q450AS3510	50/pk
	Q2100AS3510	Q3100AS3510	Q4100AS3510	100/pk

III QUANTIFOIL® with Different Hole Shapes

QUANTIFOIL® Multi A is a holey film, which consists of various pattern hole sizes, shapes and arrangements is repeated. In addition to round holes, the pattern includes ovalshaped ones, which appear round at high tilt angles (~70°). The diameters of the round holes are about 1, 1.4 and 2µ, and the bar widths range from 0.5 to 4µ. The oval holes in the foil have a dimension of 8 x 2µ and 4 x 1µ.

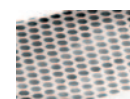


Grid Type	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
Copper	Q210CMA	Q310CMA	Q410CMA	10/pk
	Q225-CMA	Q325CMA	Q425CMA	25/pk
	Q250-CMA	Q350CMA	Q450CMA	50/pk
	Q2100CMA	Q3100CMA	Q4100CMA	100/pk
Nickel	Q210NMA	Q310NMA	Q410NMA	10/pk
	Q225-NMA	Q325NMA	Q425NMA	25/pk
	Q250-NMA	Q350NMA	Q450NMA	50/pk
	Q2100NMA	Q3100NMA	Q4100NMA	100/pk
Gold	Q210AMA	Q310AMA	Q410AMA	10/pk
	Q225AMA	Q325AMA	Q425AMA	25/pk
	Q250AMA	Q350AMA	Q450AMA	50/pk
	Q2100AMA	Q3100AMA	Q4100AMA	100/pk

III QUANTIFOIL® with Hexagonal Geometry

This type of QUANTIFOIL is meant for slot grids. It was especially designed for supporting serial thin sections. It offers an optimum between mechanical stability on the one hand and background-free area on the other hand. The foil is thin enough to allow those parts of the sections that lie on the bars to be interpreted. In this way, the information in the sections can be interpreted to the maximum.

QUANTIFOIL® Hex 15 A foil with hole size of 26µm (diameter of inscribed circle) and a repeating distance of 41µm, the side length of the holes and the bar width are 15µm.



Grid Type	Hole Size	Description	Cat. #	Pack
Copper	26µm	0.5 x 2mm slot grids	Q225CR-HEX	50/pk
			Q250CR-HEX	100/pk
Nickel	26µm	0.5 x 2mm slot grids	Q225NR-HEX	50/pk
			Q250NR-HEX	100/pk
Gold	26µm	0.5 x 2mm slot grids	Q225AR-HEX	50/pk
			Q250AR-HEX	100/pk

TEM SUPPORT FILMS

QUANTIFOIL® Holey Carbon Films (continued)

III QUANTIFOIL® on London Finder Grids

Maxtaform grids with reference patterns are of the highest consistent quality, with a wide choice to choose from to suit all your particular needs.

All other geometries and thicknesses available upon request. NOW AVAILABLE WITH ULTRATHIN CONTINUOUS CARBON.

Grid Type	Hole Size	Period	London Finder H 2 Pitch 127µ, 200 mesh	London Finder H 7 Pitch 63µ, 400 mesh	London Finder H 15 Pitch 188µ, 135 mesh	London Finder H 6 Pitch 235µ, Honeycomb	Qty.
			Cat. # H 2	Cat. # H 7	Cat. # H 15	Cat. # H 6	
QUANTIFOIL® R 1.2/1.3							
Copper	~1.2µm	2.5µm	LFH2100CR1.3	LFH7100CR1.3	LFH15100CR1.3	LFH6100CR1.3	100/pk
Gold	~1.2µm	2.5µm	LFH2100AR1.3	LFH7100AR1.3	LFH15100AR1.3	LFH6100AR1.3	100/pk
QUANTIFOIL® R 1.2/1.3 with Ultrathin Carbon							
Copper	~1.2µm	2.5µm	LFH2100CR1.3-2nm	LFH7100CR1.3-2nm	LFH15100CR1.3-2nm	LFH6100CR1.3-2nm	100/pk
Gold	~1.2µm	2.5µm	LFH2100AR1.3-2nm	LFH7100AR1.3-2nm	LFH15100AR1.3-2nm	LFH6100AR1.3-2nm	100/pk
QUANTIFOIL® R 2/1							
Copper	2µm	3µm	LFH2100CR1	LFH7100CR1	LFH15100CR1	LFH6100CR1	100/pk
Gold	2µm	3µm	LFH2100AR1	LFH7100AR1	LFH15100AR1	LFH6100AR1	100/pk
QUANTIFOIL® R 2/1 with Ultrathin Carbon							
Copper	2µm	3µm	LFH2100CR1-2nm	LFH7100CR1-2nm	LFH15100CR1-2nm	LFH6100CR1-2nm	100/pk
Gold	2µm	3µm	LFH2100AR1-2nm	LFH7100AR1-2nm	LFH15100AR1-2nm	LFH6100AR1-2nm	100/pk
QUANTIFOIL® R 2/2							
Copper	2µm	4µm	LFH2100CR2	LFH7100CR2	LFH15100CR2	LFH6100CR2	100/pk
Gold	2µm	4µm	LFH2100AR2	LFH7100AR2	LFH15100AR2	LFH6100AR2	100/pk
QUANTIFOIL® R 2/2 with Ultrathin Carbon							
Copper	2µm	4µm	LFH2100CR2-2nm	LFH7100CR2-2nm	LFH15100CR2-2nm	LFH6100CR2-2nm	100/pk
Gold	2µm	4µm	LFH2100AR2-2nm	LFH7100AR2-2nm	LFH15100AR2-2nm	LFH6100AR2-2nm	100/pk
QUANTIFOIL® R 2/4							
Copper	2µm	6µm	LFH2100CR4	LFH7100CR4	LFH15100CR4	LFH6100CR4	100/pk
Gold	2µm	6µm	LFH2100AR4	LFH7100AR4	LFH15100AR4	LFH6100AR4	100/pk
QUANTIFOIL® R 2/4 with Ultrathin Carbon							
Copper	2µm	6µm	LFH2100CR4-2nm	LFH7100CR4-2nm	LFH15100CR4-2nm	LFH6100CR4-2nm	100/pk
Gold	2µm	6µm	LFH2100AR4-2nm	LFH7100AR4-2nm	LFH15100AR4-2nm	LFH6100AR4-2nm	100/pk
QUANTIFOIL® R 3.5/1							
Copper	3.5µm	4.5µm	LFH2100CR35	LFH7100CR35	LFH15100CR35	LFH6100CR35	100/pk
Gold	3.5µm	4.5µm	LFH2100AR35	LFH7100AR35	LFH15100AR35	LFH6100AR35	100/pk
QUANTIFOIL® R 3.5/1 with Ultrathin Carbon							
Copper	3.5µm	4.5µm	LFH2100CR35-2nm	LFH7100CR35-2nm	LFH15100CR35-2nm	LFH6100CR35-2nm	100/pk
Gold	3.5µm	4.5µm	LFH2100AR35-2nm	LFH7100AR35-2nm	LFH15100AR35-2nm	LFH6100AR35-2nm	100/pk

QUANTIFOIL® Holey SiO₂ Films

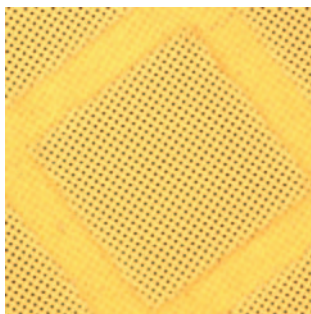
III QUANTIFOIL® – Holey SiO₂ Films

The currently favored and already established material other than carbon is SiO₂.

Grid Type	Hole Size	Period	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.	Grid Type	Hole Size	Period	Cat. # 200 Mesh	Cat. # 300 Mesh	Cat. # 400 Mesh	Qty.
R 1/4							R 2/2						
Copper	1µm	5µm	Q250CR-14S	Q350CR-14S	Q450CR-14S	100/pk	Copper	2µm	4µm	Q2100CR-4S	Q3100CR-4S	Q4100CR-4S	100/pk
Nickel	1µm	5µm	Q250NR-14S	Q350NR-14S	Q450NR-14S	100/pk	Nickel	2µm	4µm	Q2100NR-4S	Q3100NR-4S	Q4100NR-4S	100/pk
Gold	1µm	5µm	Q250AR-14S	Q350AR-14S	Q450AR-14S	100/pk	Gold	2µm	4µm	Q2100AR-4S	Q3100AR-4S	Q4100AR-4S	100/pk
R 1.2/1.3							R 2/4						
Copper	1.2µm	2.5µm	Q2100CR1.3S	Q3100CR2.5S	Q4100CR2.5S	100/pk	Copper	2µm	6µm	Q2100CR-4S	Q3100CR4S	Q4100CR4S	100/pk
Nickel	1.2µm	2.5µm	Q2100NR1.3S	Q3100NR2.5S	Q4100NR2.5S	100/pk	Nickel	2µm	6µm	Q2100NR-4S	Q3100NR4S	Q4100NR4S	100/pk
R 1.2/20							R 2/4						
Copper	1.2µm	21.2µm	Q2100CR21.2S	Q3100CR21.2S	Q4100CR21.2S	100/pk	Gold	2µm	6µm	Q2100AR-4S	Q3100AR4S	Q4100AR4S	100/pk
Nickel	1.2µm	21.2µm	Q2100NR21.2S	Q3100NR21.2S	Q4100NR21.2S	100/pk							

III UltrAuFoil™ Holey Gold Films

These newly developed ultrastable gold supports for electron cryomicroscopy will reduce the movement of frozen specimens during imaging. This improves image contrast and quality, leading to better 3D reconstructions with less data.



During imaging at cryo-temperatures, traditional carbon supports move, particularly at the beginning of irradiation. This movement blurs images and makes it difficult to determine the structures of small and challenging molecules.

Using UltrAuFoil™, designed at MRC's Laboratory of Molecular Biology by Dr Christopher J. Russo and Dr Lori A. Passmore and produced by Quantifoil Micro Tools, specimen motion can be reduced significantly. (For details see: Ultrastable gold substrates for electron cryomicroscopy, Science, 2014, Vol. 346 no. 6215 pp. 1377-1380).

Characteristics of UltrAuFoil™

Thickness of Gold Foil	about 500 Å
Structure of Gold Foil	regular square array of micrometer-sized circular holes

Ordering Information

All other geometries and thicknesses available upon request

Grid Type	Hole Size	Period	Cat. # 200 Mesh	Cat. # 300 Mesh	Qty.
R 0.6/1					
Gold	0.6µm	1.6µm	—	Q350AR1A	50/pk
R 1.2/1.3					
Gold	1.2µm	2.5µm	—	Q350AR13A	50/pk
R 2/2					
Gold	2µm	4µm	Q250AR2A	—	50/pk

FREQUENTLY ASKED QUESTIONS ABOUT... UltrAuFoil™ Holey Gold Films

Why is the foil made of gold? Because it is a highly conductive, nonoxidizing, radiation-hard material whose surface is chemically inert and biocompatible.

Why is the foil 500 Å thick? 400-500 Å is optimal because it minimizes motion as much as thicker layers but still gives thin ice films under typical blotting conditions. Below 400 Å, the performance of the gold support foils begins to degrade.

Why is the TEM grid made of gold? Using the same metal eliminates differential thermal contraction during cooling of the sample and therefore prevents changes in the geometry and tension of the support foil.

How should I store the UltrAuFoil™ and within which time should I use them?

The UltrAuFoil™ like our other products should be stored in a grid storage box in a dark, cool and low-humidity environment. Generally there is no date of expiry, but we recommend to use them within two years.

Do I need to modify the UltrAuFoil™ before use? No, they are ready for use when delivered. They can be made more hydrophilic using standard glow discharge and plasma systems or other gold surface treatments.

How do I set up the beam for data collection? Currently, the recommended electron beam geometry is circularly symmetric beam, centered on the hole, which encompasses a small region of the support around each hole. The micrograph is taken in the center of the hole.

How do I focus using UltrAuFoil™? Since there is no amorphous material in the gold support structure, Thon rings cannot be used to focus. As discussed in the publication, several other options are available, but the two simplest are:

1. Turn on beam tilt wobble and minimize the image shift.
2. Look for the diffracted beams at the edge of a hole with the objective aperture removed. When the shift between the diffracted beams and the crystals of gold is minimized, the foil is in focus.

How do I correct the astigmatism? We recommend using a calibration specimen to correct the stigmatism and beam tilt prior to collecting data on UltrAuFoil™.

Can I use automated data collection methods? Yes, automated data collection has been successfully tested on UltrAuFoil™ using beam tilt to focus.

Are UltrAuFoil™ fragile? No, they are similar or less fragile than traditional carbon foils. But if mishandled with tweezers or broken during freeze plunging, the stability of the support may be severely degraded. We recommend collecting data only from squares where the foil is uniform and intact.

Can I add a continuous film of amorphous carbon? Yes. Standard float transfer methods work fine for transferring thin films of carbon onto UltrAuFoil™.

YOU MAY NEED...

Look for these items and more in our digital catalog, or visit www.emsdiasum.com

TEM Checker

Monitor the performance of your x-ray detectors. Contains (5) 3mm dia. manganese disks in a standard grid storage box.



GloQube® Plus

Glow Discharge System for TEM Grids and Surface Modification

Applications:

- Hydrophilization and cleaning of TEM grids carbon support films (typically: Formvar®, Lacey Carbon, Holey Carbon, Continuous Carbon, Quantifoil® for better sample spreading)
- Improved adhesion and orientation of proteins, nucleic acids and antibodies
- TEM grid preparation for nanoparticle studies



TEM SUPPORT FILMS

Graphene Support Films for TEM

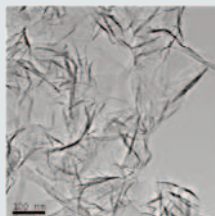
Overview

Graphene is a single atomic layer of carbon atoms tightly packed in a two-dimensional honeycomb lattice. This novel material is atomically thin, chemically inert, consists of light atoms, and possesses a highly ordered structure. Graphene is electrically and thermally conductive, and is the strongest material ever measured. These remarkable properties make graphene the ideal support film for electron microscopy.

Potential Applications:

Biodevices
Single Molecule Gas Detection
Graphene Nanoribbon Integrated Circuits
Transparent Conducting Electrodes
Ultracapacitors

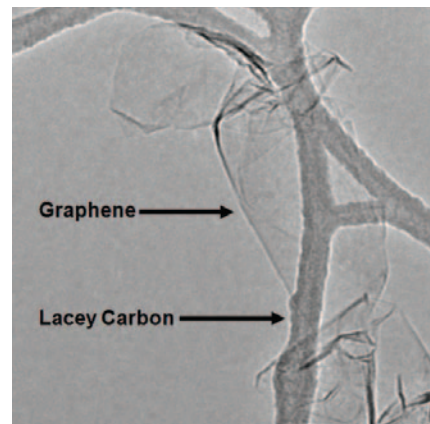
A typical low-magnification TEM image of crumpled and randomly oriented large-area graphene sheets suspended on a lacey carbon TEM grid.

**Synthesis**

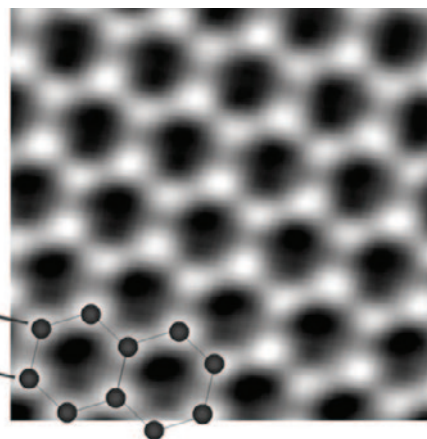
the substrate-free gas-phase method

Graphene is a single atomic layer of carbon atoms tightly packed in a two-dimensional honeycomb lattice. The novel material has generated great interest throughout the scientific and technological community because of its remarkable properties and numerous potential applications. However, obtaining pure and highly ordered graphene has been a challenge. Small quantities of ultrahigh-quality graphene have been isolated through an unwieldy and time-consuming process involving the mechanical exfoliation of highly oriented pyrolytic graphite. Alternative methods require substrates or graphite to create atomically-thin sheets, and these techniques involve multiple steps, expensive substrates, or non-ambient conditions. Furthermore, the sheets produced by these alternative methods exhibit defects, disorder, and oxygen functionalities that have a detrimental effect on the properties of graphene.

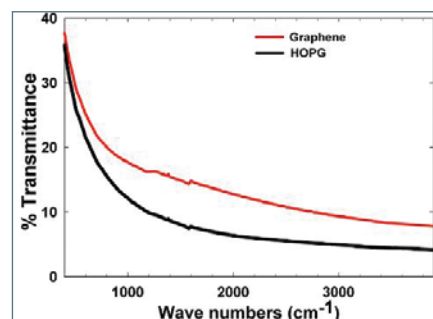
The substrate-free gas-phase method is the first and only process that can synthesize ultrahigh-quality graphene in a single step, without the use of substrates or graphite [1]. Graphene sheets are created through the delivery of liquid alcohol droplets directly into atmospheric-pressure microwave-generated plasmas. Extensive characterization of the synthesized graphene has proven that the sheets are oxygen-free and exhibit a highly ordered structure [2]. The graphene produced by this unique method can immediately be utilized for graphene applications.



A typical TEM image of graphene sheets freely suspended on a lacey carbon TEM grid.



An atomic-resolution image of a clean and structurally perfect graphene sheet synthesized by the substrate-free gas-phase method. Individual carbon atoms appear white in the image.



Elemental analysis by FT-IR reveals that the synthesized graphene sheets are free of detrimental oxygen functionalities. The FT-IR spectrum of synthesized graphene is similar to that of highly oriented pyrolytic graphite (HOPG).

Graphene Support Films for TEM (continued)

Application**Direct imaging of soft and hard nanomaterials**

The interfaces between soft and hard nanomaterials have been the subject of extensive research.

Nanoparticles coated with molecular layers have been shown to self-assemble into novel structures that could potentially be used in electronics, sensors, and photonics. Self-assembly is influenced by the nature of molecular coatings and thus more detailed characterization of these soft materials is needed.

However, imaging surface molecules and their interfaces with nanoparticles at the atomic scale is a significant challenge. The transmission electron microscope (TEM) imaging of functionalized nanoparticles has been attempted.

However, it has not been possible to observe molecular surface layers and their interfaces with nanoparticles at the atomic level. Modern aberration-corrected TEMs can produce atomic-resolution images of soft and hard nanomaterials. However, conventional TEM support films (e.g. ultrathin amorphous carbon) limit the capabilities of these advanced microscopes because they contribute to overall electron scattering and diminish the contrast of low-atomic number specimens. The TEM imaging of the interfaces between soft and hard nanomaterials therefore requires better support films that have a lower dynamical interference with an imaging object [3].

Graphene is the ideal TEM support film. The material possesses a highly ordered structure and is atomically thin, chemically inert, structurally stable, and electrically and thermally conductive. The ultrahigh-quality graphene produced by the substrate-free gas-phase method [1, 2] has enabled the unsurpassed TEM imaging of organic molecules and the interfaces between soft and hard nanomaterials. The pure and highly-ordered sheets were used as a near-invisible support film to directly image the atoms in a gold nanoparticle and its surrounding citrate coating [3]. The results showed that the synthesized graphene can be used to directly observe nanoparticles functionalized with a diverse range of molecular coatings, such as proteins and DNA

We offer ultrahigh-quality graphene that is produced through the substrate-free gas-phase method[1]. The graphene created by this technique possesses a highly ordered structure that is composed of 99% carbon by mass (1% hydrogen)[2]. This graphene was used to directly image gold nanoparticles and their organic surface molecules in both conventional and

atomic-resolution TEMs at a level that greatly surpasses any current TEM support film[3].

Our graphene provides an invisible, crystalline background that enables the unrivaled TEM characterization of organic and inorganic nanomaterials.

References:

[1] Dato et al., "Substrate-Free Gas-Phase Synthesis of Graphene Sheets", *Nano Letters* 8, 2012–2016 (2008).

[2] Dato et al., "Clean and highly ordered graphene synthesized in the gas phase", *Chemical Communications*, 6095–6097, (2009).

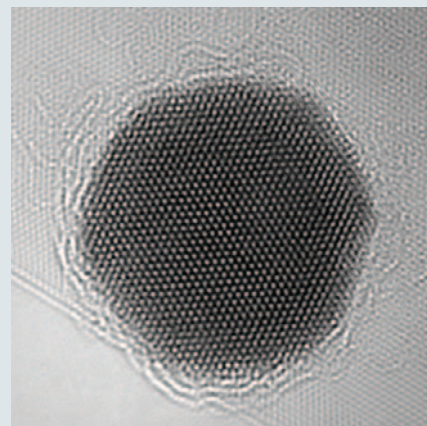
[3] Lee et al., "Direct Imaging of Soft-Hard Interfaces

Additional References:

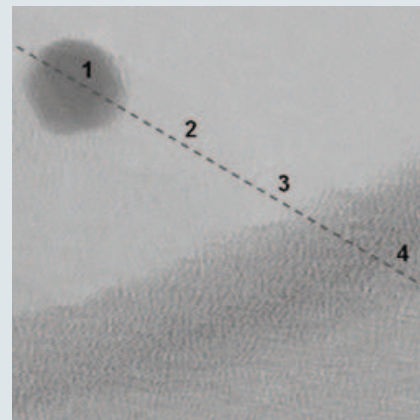
Galatzer-Levy, J. Graphene "sandwich" improves imaging of biomolecules. University of Illinois at Chicago News Center Web Site. February 4, 2014. Available at: <http://news.uic.edu/graphene-sandwich-improves-imaging-of-biomolecules>. Accessed February 12, 2014.

Wang, C., Qiao, Q., Shokuhfar, T. and Klie, R. F. (2014), High-Resolution Electron Microscopy and Spectroscopy of Ferritin in Biocompatible Graphene Liquid Cells and Graphene Sandwiches. *Adv. Mater.* doi: 10.1002/adma.201306069

Dato, A. and Frenklach, M., "Substrate-free microwave synthesis of graphene: experimental conditions and hydrocarbon precursors", *New Journal of Physics*, 12, 1367-2630 (2010).



An atomic-resolution image of a 10 nm gold nanoparticle and its surrounding citrate capping agent on a synthesized graphene support film.



A low-magnification image of a (1) gold nanoparticle 10 nm in diameter on a (2) transparent synthesized graphene support film, (3) the vacuum, and (4) a lacey carbon support.

Ordering Information

Graphene products come available in five different ways, allowing you to choose which is best for you

- As a solution of 0.1 mg Graphene in 1 ml of Ethanol. A homogeneous solution will take less than 30 seconds to create by sonicating the Graphene-solvent mixture. One is able to coat their own grids using this solution.
- As Graphene-enhanced lacey carbon TEM grids. 200 and 300 mesh. These grids are created by coating our existing lacey carbon grids with graphene. Through a unique drop method, solution is dispersed onto the Lacey Carbon Grid.
- As dry, synthesized Graphene powder, 1 mg.



Cat. No.	Description	Qty.
GF1200	0.1 mg Graphene in 1 ml of Ethanol	each
GF1201	Graphene-Enhanced Lacey Carbon TEM Grid 200 # Cu	each
GF1202	Graphene-Enhanced Lacey Carbon TEM Grid 200 # Ni	each
GF1203	Graphene-Enhanced Lacey Carbon TEM Grid 300 # Cu	each
GF1204	Graphene-Enhanced Lacey Carbon TEM Grid 300 # Ni	each
GF1205	Synthesized Graphene Powder, 1 mg	each

TEM SUPPORT FILMS

Graphene Support Films for TEM (continued)

III Graphene on Lacey Carbon 300 Mesh Copper TEM Grids

CAS No. 7782-42-5

Characteristics

- Four thicknesses of CVD graphene. Available in either 1, 2, 3-5 or 6-8 layers.
- TEM Substrate: Lacey carbon support film on 300 mesh copper TEM grid.
- Graphene coverage of the TEM grid is better than 75%.

Appearance

The graphene film appears as a near-transparent to light-grey film on the surface of the Lacey Carbon mesh on a red-brown colored copper TEM grid.

Specifications

Type	Graphene Thickness	Transparency	TEM Grid/AFM Substrate	Support Film
1 Layer	~0.35 nm	~96.4%	300 Mesh Copper Grid	Lacey Carbon
2 Layers	~0.7 nm	~92.7%		
3-5 Layers	1.0-1.7 nm	~85.8-90.4%		
6-8 Layers	2.1-2.8 nm	~78.5-83.2%		

Ordering Information

Cat. No.	Description	Qty.	Cat. No.	Description	Qty.
1 Layer			3-5 Layers		
1GLC300Cu-5	Graphene on Lacey Carbon, 300 Cu	5/pk	3GLC300Cu-5	Graphene on Lacey Carbon, 300 Cu	5/pk
1GLC300Cu-10	Graphene on Lacey Carbon, 300 Cu	10/pk	3GLC300Cu-10	Graphene on Lacey Carbon, 300 Cu	10/pk
1GLC300Cu-25	Graphene on Lacey Carbon, 300 Cu	25/pk	3GLC300Cu-25	Graphene on Lacey Carbon, 300 Cu	25/pk
2 Layers			6-8 Layers		
2GLC300Cu-5	Graphene on Lacey Carbon, 300 Cu	5/pk	6GLC300Cu-5	Graphene on Lacey Carbon, 300 Cu	5/pk
2GLC300Cu-10	Graphene on Lacey Carbon, 300 Cu	10/pk	6GLC300Cu-10	Graphene on Lacey Carbon, 300 Cu	10/pk
2GLC300Cu-25	Graphene on Lacey Carbon, 300 Cu	25/pk	6GLC300Cu-25	Graphene on Lacey Carbon, 300 Cu	25/pk

III Graphene on Ultra-Fine 2000 Mesh Copper TEM Grids

CAS No. 7782-42-5

Characteristics

- Four thicknesses of CVD graphene. Available in either 1, 2, 3-5 or 6-8 layers.
- TEM Substrate: Microporous Copper TEM Grids with Beryllium-Copper Support Aperture.
- Graphene coverage of the TEM grid is better than 75%.

Appearance

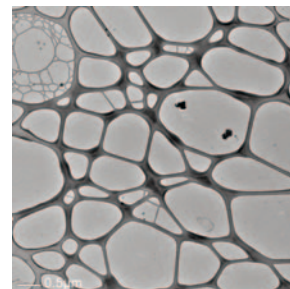
The graphene film appears as a near-transparent to light-grey film on the surface of the red-brown microporous copper TEM grid. For support, the TEM grid is attached using epoxy to a gold-colored beryllium-copper disk with a 2 x 1 mm aperture.

Specifications

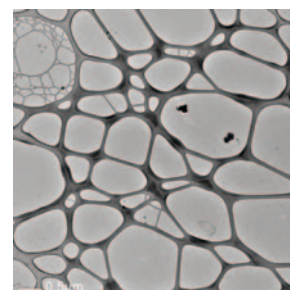
Type	Graphene Thickness	Transparency	TEM Grid/AFM Substrate	Support Film
1 Layer	~0.35 nm	~96.4%	2000 Mesh Copper Grid	N/A
2 Layers	~0.7 nm	~92.7%		
3-5 Layers	1.0-1.7 nm	~85.8-90.4%		
6-8 Layers	2.1-2.8 nm	~78.5-83.2%		

Ordering Information

Cat. No.	Description	Qty.	Cat. No.	Description	Qty.
1 Layer			3-5 Layers		
1GLC2000Cu-5	Graphene on Ultra-Fine, 2000 Cu	5/pk	3GLC2000Cu-5	Graphene on Ultra-Fine, 2000 Cu	5/pk
1GLC2000Cu-10	Graphene on Ultra-Fine, 2000 Cu	10/pk	3GLC2000Cu-10	Graphene on Ultra-Fine, 2000 Cu	10/pk
1GLC2000Cu-25	Graphene on Ultra-Fine, 2000 Cu	25/pk	3GLC2000Cu-25	Graphene on Ultra-Fine, 2000 Cu	25/pk
2 Layers			6-8 Layers		
2GLC2000Cu-5	Graphene on Ultra-Fine, 2000 Cu	5/pk	6GLC2000Cu-5	Graphene on Ultra-Fine, 2000 Cu	5/pk
2GLC2000Cu-10	Graphene on Ultra-Fine, 2000 Cu	10/pk	6GLC2000Cu-10	Graphene on Ultra-Fine, 2000 Cu	10/pk
2GLC2000Cu-25	Graphene on Ultra-Fine, 2000 Cu	25/pk	6GLC2000Cu-25	Graphene on Ultra-Fine, 2000 Cu	25/pk



Low magnification TEM image of single-layer graphene on lacey carbon film. Typical grain size is in the region of 2-3 μm



Low magnification TEM image of single-layer graphene on lacey carbon film. Typical grain size is in the region of 2-3 μm

Graphene Support Films for TEM (continued)

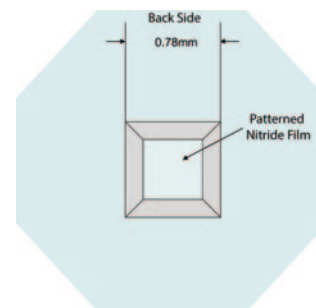
III Graphene on Silicon Nitride TEM Grids (2.5 μm holes)

Characteristics

- Four thicknesses of CVD graphene. Available in either 1, 2, 3-5 or 6-8 layers.
- TEM Substrate: 200 μm thick 3.0mm hexagonal silicon substrate with a 0.5 x 0.5 mm aperture and 200 nm thick silicon nitride membrane with approximately 6,400 2.5 μm holes.
- Graphene coverage of the TEM grid is better than 75%.

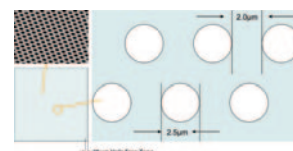
Appearance

Solid hexagonal disk with a greenish hue. The graphene film appears as a near-transparent to light-grey film on the surface of the microporous Silicon Nitride membrane.



Specifications

Type	Graphene Thickness	Transparency	TEM Grid/AFM Substrate	Support Film
1 Layer	~0.35 nm	~96.4%	Hexagonal Silicon	Silicon Nitride with 2.5 μm Holes
2 Layers	~0.7 nm	~92.7%		
3-5 Layers	1.0-1.7 nm	~85.8-90.4%		
6-8 Layers	2.1-2.8 nm	~78.5-83.2%		



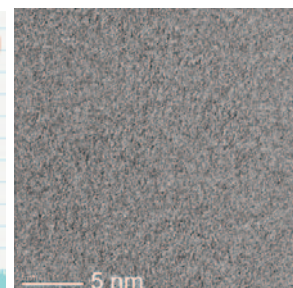
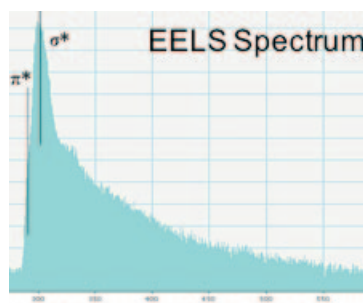
Ordering Information

Cat. No.	Description	Qty.	Cat. No.	Description	Qty.
1 Layer			3-5 Layers		
1GSiN2.5um-5	Graphene on Silicon Nitride, 2.5 μm	5/pk	3GSiN2.5um-5	Graphene on Silicon Nitride, 2.5 μm	5/pk
1GSiN2.5um-10	Graphene on Silicon Nitride, 2.5 μm	10/pk	3GSiN2.5um-10	Graphene on Silicon Nitride, 2.5 μm	10/pk
1GSiN2.5um-25	Graphene on Silicon Nitride, 2.5 μm	25/pk	3GSiN2.5um-25	Graphene on Silicon Nitride, 2.5 μm	25/pk
2 Layers			6-8 Layers		
2GSiN2.5um-5	Graphene on Silicon Nitride, 2.5 μm	5/pk	6GSiN2.5um-5	Graphene on Silicon Nitride, 2.5 μm	5/pk
2GSiN2.5um-10	Graphene on Silicon Nitride, 2.5 μm	10/pk	6GSiN2.5um-10	Graphene on Silicon Nitride, 2.5 μm	10/pk
2GSiN2.5um-25	Graphene on Silicon Nitride, 2.5 μm	25/pk	6GSiN2.5um-25	Graphene on Silicon Nitride, 2.5 μm	25/pk

III Graphene on Ultra-Flat Thermal SiO₂ Substrate

Characteristics

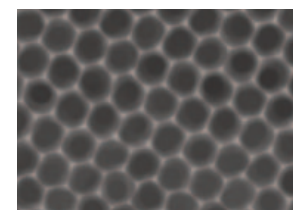
- Four thicknesses of CVD graphene. Available in either 1, 2, 3-5 or 6-8 layers.
- TEM Substrate: The Ultra-flat Thermal SiO₂ Substrate consists of a 200 nm thermally grown SiO₂ film on an ultra-flat silicon wafer with a normal thickness of 675 μm . The size is 5 mm x 5 mm.
- Graphene coverage of the TEM grid is better than 75%.



STEM-MAADF image by Kotakoski, et al.

Specifications

Type	Graphene Thickness	Transparency	TEM Grid/AFM Substrate	Support Film
1 Layer	~0.35 nm	~96.4%	Ultra-Flat Silicon	Thermally Grown SiO ₂
2 Layers	~0.7 nm	~92.7%		
3-5 Layers	1.0-1.7 nm	~85.8-90.4%		
6-8 Layers	2.1-2.8 nm	~78.5-83.2%		



Ordering Information

Cat. No.	Description	Qty.	Cat. No.	Description	Qty.
1 Layer			3-5 Layers		
1GUFsiO2-5	Graphene on Ultra-Flat Thermal SiO ₂	5/pk	3GUFsiO2-5	Graphene on Ultra-Flat Thermal SiO ₂	5/pk
1GUFsiO2-10	Graphene on Ultra-Flat Thermal SiO ₂	10/pk	3GUFsiO2-10	Graphene on Ultra-Flat Thermal SiO ₂	10/pk
1GUFsiO2-25	Graphene on Ultra-Flat Thermal SiO ₂	25/pk	3GUFsiO2-25	Graphene on Ultra-Flat Thermal SiO ₂	25/pk
2 Layers			6-8 Layers		
2GUFsiO2-5	Graphene on Ultra-Flat Thermal SiO ₂	5/pk	6GUFsiO2-5	Graphene on Ultra-Flat Thermal SiO ₂	5/pk
2GUFsiO2-10	Graphene on Ultra-Flat Thermal SiO ₂	10/pk	6GUFsiO2-10	Graphene on Ultra-Flat Thermal SiO ₂	10/pk
2GUFsiO2-25	Graphene on Ultra-Flat Thermal SiO ₂	25/pk	6GUFsiO2-25	Graphene on Ultra-Flat Thermal SiO ₂	25/pk

TEM SUPPORT FILMS

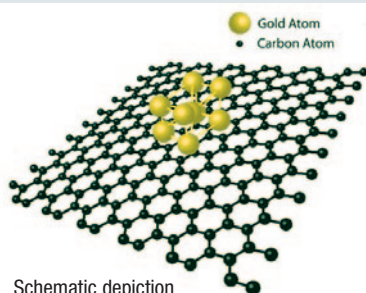
Graphene Oxide Support Films for TEM

Graphene Oxide Membranes

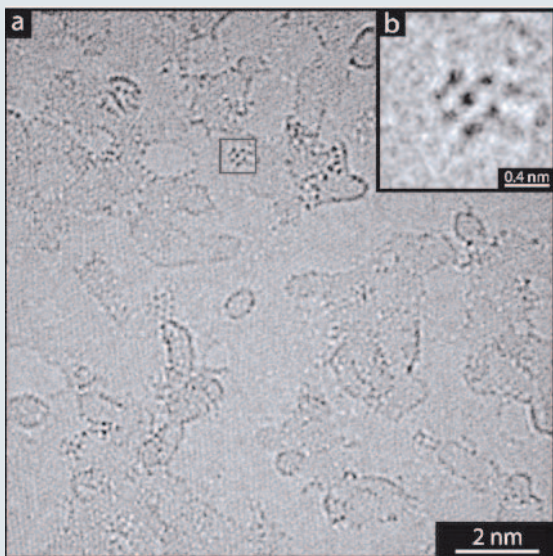
A Scalable and Efficient Application of 2D Materials

Since the first report on producing the two-dimensional (2D) material graphene in 2004, there has been considerable time and money invested into developing new graphene-based technologies. These aim to exploit the remarkable

properties of graphene including its strength and electrical- and thermal- conductivity. At a basic level, transmission electron microscopy (TEM) image contrast is caused by the scattering of electrons and is dependent on the thickness and composition of the sample material. The ultimate thinness of graphene, combined with the low atomic number of carbon, provides the ideal blueprint for a low-contrast TEM support. Producing graphene and transferring onto a TEM support grid is difficult to carry out at large scale and high yield. A simpler, cheaper, and higher yield production method uses graphene oxide, a 2D material similar to graphene. Graphite is reduced using a strong oxidising agent, and the oxygen functionalities introduced render it hydrophilic, allowing it to be easily dispersed in water, as well as other organic solvents. Controlled sonication of the water-dispersed material allows finely-tuned exfoliation of the graphene oxide, which in turn allows samples, including TEM supports, to be coated in single or few-layer graphene oxide. These flakes possess the low contrast benefits of graphene, which, combined with the efficient production of graphene oxide, make it ideal as a cheap, high-yield TEM support.



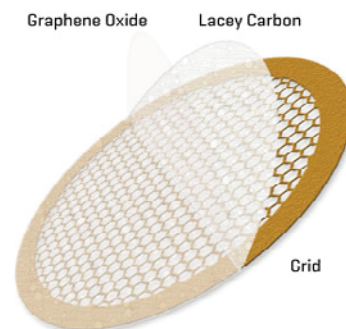
Schematic depiction of image b (below) in 3D. Adapted from Bosch-Navarro.



a) A high-resolution TEM image showing gold nanoparticles dispersed across modified graphene-oxide.
b) Magnified image of red-box area in image a, showing single gold-nanoparticles with atomic resolution.

Graphene Oxide TEM Support Films

Graphene Oxide (GO) support film is a super thin (<1nm), naturally hydrophilic layer placed over the Holey, Lacey or Quantifoil support film on copper or gold grids. Pre-treatment of GO Support Films is unnecessary - by default, the hydrophilic surface spreads particles evenly across the grid. A hydrophobic surface can be achieved by heating in the air. Note: plasma cleaning or glow discharge will damage the support film.



Features

- Works well with Holey Carbon, Lacey Carbon and Quantifoil grid types, effectively spanning the gaps
- Less expensive to produce due to complexity of graphene manufacturing
- Better background contrast than graphene, results in higher resolution
- Nearly transparent in electron beam
- Barely visible under optical microscopes
- Regular batch checking ensures correct coverage of monolayers

Ordering Information

Graphene Oxide on Holey Carbon Copper Mesh Grids

Cat. No.	Film	Grid	Mesh	Qty
GOHC300Cu10	GO on Holey Carbon	Cu	300	10/pk
GOHC300Cu25	GO on Holey Carbon	Cu	300	25/pk
GOHC300Cu50	GO on Holey Carbon	Cu	300	50/pk

Graphene Oxide on Lacey Carbon Copper Mesh Grids

Cat. No.	Film	Grid	Mesh	Qty
GOLC300Cu10	GO on Lacey Carbon	Cu	300	10/pk
GOLC300Cu25	GO on Lacey Carbon	Cu	300	25/pk
GOLC300Cu50	GO on Lacey Carbon	Cu	300	50/pk
GOLC300Cu100	GO on Lacey Carbon	Cu	300	100/pk

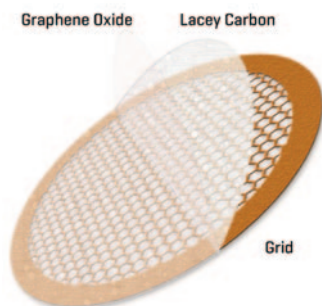
Graphene Oxide on Quantifoil Grids

Copper and Gold versions available

Cat. No.	Film	Grid	Mesh	Qty
GOQ200R24Cu10	GO on Quantifoils R2/4	Cu	200	10/pk
GOQ200R24Cu25	GO on Quantifoils R2/4	Cu	200	25/pk
GOQ200R24Cu50	GO on Quantifoils R2/4	Cu	200	50/pk
GOQ300R22Cu10	GO on Quantifoils R2/2	Cu	300	10/pk
GOQ300R22Cu25	GO on Quantifoils R2/2	Cu	300	25/pk
GOQ300R24Cu10	GO on Quantifoils R2/4	Cu	300	10/pk
GOQ300R24Cu25	GO on Quantifoils R2/4	Cu	300	25/pk
GOQ300R24Cu50	GO on Quantifoils R2/4	Cu	300	50/pk
GOQ400R1213Au10	GO on Quantifoils R1.2/1.3	Au	400	10/pk
GOQ400R1213Au25	GO on Quantifoils R1.2/1.3	Au	400	25/pk
GOQ400R1213Au50	GO on Quantifoils R1.2/1.3	Au	400	50/pk
GOQ400R1213Cu10	GO on Quantifoils R1.2/1.3	Cu	400	10/pk
GOQ400R1213Cu25	GO on Quantifoils R1.2/1.3	Cu	400	25/pk
GOQ400R1213Cu50	GO on Quantifoils R1.2/1.3	Cu	400	50/pk
GOQ400R1213Cu100	GO on Quantifoils R1.2/1.3	Cu	400	100/pk

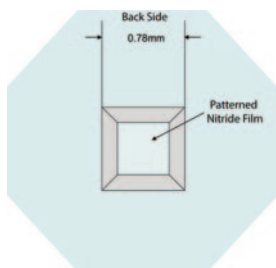
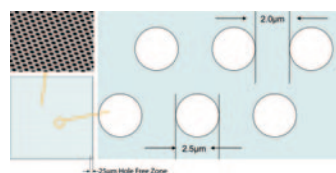
Graphene Oxide Support Films for TEM (continued)

Graphene Oxide on Lacey Carbon 300 Mesh Copper TEM Grids



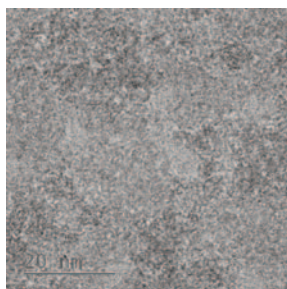
Cat. No.	Description	Qty.
1 Layer		
1GOLC300Cu-5	Graphene Oxide on Lacey Carbon, 300 Cu	5/pk
1GOLC300Cu-10	Graphene Oxide on Lacey Carbon, 300 Cu	10/pk
1GOLC300Cu-25	Graphene Oxide on Lacey Carbon, 300 Cu	25/pk
2 Layers		
2GOLC300Cu-5	Graphene Oxide on Lacey Carbon, 300 Cu	5/pk
2GOLC300Cu-10	Graphene Oxide on Lacey Carbon, 300 Cu	10/pk
2GOLC300Cu-25	Graphene Oxide on Lacey Carbon, 300 Cu	25/pk

Graphene Oxide on Silicon Nitride, 2.5 μm



Cat. No.	Description	Qty.
1 Layer		
1GOSiN2.5um-5	Graphene Oxide on Silicon Nitride, 2.5 μm	5/pk
1GOSiN2.5um-10	Graphene Oxide on Silicon Nitride, 2.5 μm	10/pk
1GOSiN2.5um-25	Graphene Oxide on Silicon Nitride, 2.5 μm	25/pk
2 Layers		
2GOSiN2.5um-5	Graphene Oxide on Silicon Nitride, 2.5 μm	5/pk
2GOSiN2.5um-10	Graphene Oxide on Silicon Nitride, 2.5 μm	10/pk
2GOSiN2.5um-25	Graphene Oxide on Silicon Nitride, 2.5 μm	25/pk

Graphene Oxide on Ultra-Flat Thermal SiO₂



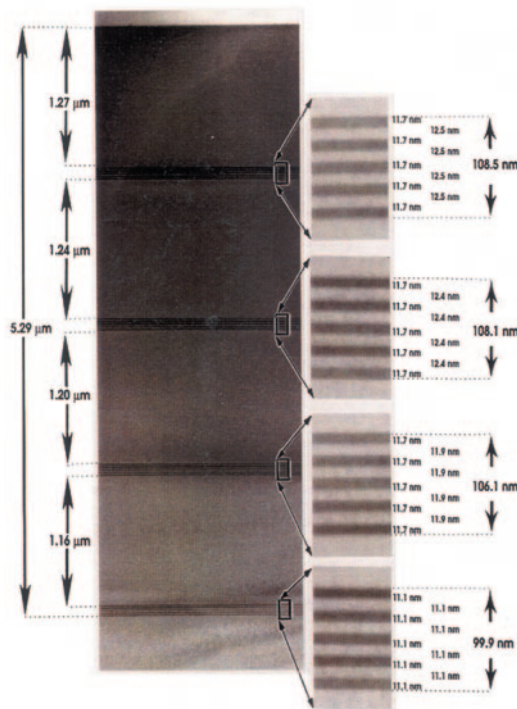
Cat. No.	Description	Qty.
1 Layer		
1GOUFSiO2-5	Graphene Oxide on Ultra-Flat Thermal SiO ₂	5/pk
1GOUFSiO2-10	Graphene Oxide on Ultra-Flat Thermal SiO ₂	10/pk
1GOUFSiO2-25	Graphene Oxide on Ultra-Flat Thermal SiO ₂	25/pk
2 Layers		
2GOUFSiO2-5	Graphene Oxide on Ultra-Flat Thermal SiO ₂	5/pk
2GOUFSiO2-10	Graphene Oxide on Ultra-Flat Thermal SiO ₂	10/pk
2GOUFSiO2-25	Graphene Oxide on Ultra-Flat Thermal SiO ₂	25/pk

YOU MAY NEED...

MAGICAL® TEM Calibration

The MAG**I**CAL® performs all major TEM calibrations:

- All TEM magnification ranges
- Camera constant
- Image Diffraction Pattern Rotation
- Directly traceable to a natural constant



MAG**I**CAL® consists of an ion milled cross section of a silicon single crystal consisting of a series of atomically flat layers of Si and SiGe, which have been grown epitaxially by MBE (molecular beam epitaxy). When the calibration structure is viewed in a TEM, it appears as a series of light and dark layers where the layer thicknesses are accurately known. The calibrated thickness measurements of these light (silicon) and dark (SiGe) layers are based on careful TEM measurements of the <111> lattice spacing of silicon, which is visible on the calibration sample itself, and are supported by x-ray diffraction measurements. The layer spacing are designed so that the sample can be used to calibrate the entire magnification range in a TEM, from 1,000x to 1,000,000x. As the sample is also a single crystal of silicon, the calibrations requiring electron diffraction information such as the camera constant and image/diffraction pattern rotation can also be performed easily and unambiguously. One single calibration sample can therefore be used to provide all three of the major TEM instrument calibration at all magnifications and all camera lengths.

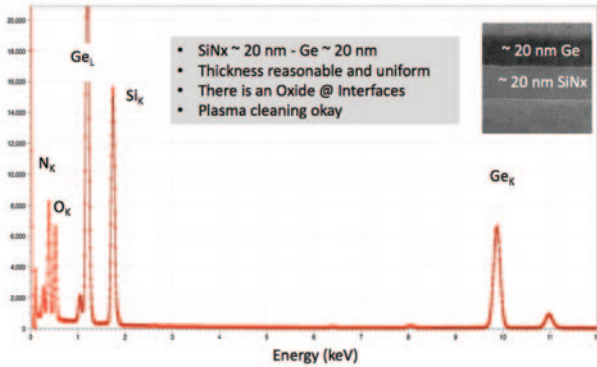
For a complete reference and technical information on MAG**I**CAL™, see our website.

Cat. No.	Description	Qty.
80069	MAG* <i>I</i> *CAL®	each

TEM WINDOW GRIDS

EDX/XEDS Calibration TEM Window Grid

Suspended germanium provides a unique calibration standard for x-ray energy dispersive spectroscopy.



Since Ge is not typically found in TEM columns, the calibration samples provide a material that cannot be mistaken for instrument components and their signal peaks. The regime in which system peaks normally occur [2-9 keV and 11-20 keV] is devoid of peaks from the Ge.

The Ge is suspended across two micron pores that are patterned on a grid of 20 nm thick silicon nitride.

The single 500 x 500 micron window is compatible with high tilt angle tomography, since at 70 degrees of tilt, the thin and beveled 100 micron silicon frame allows you to use a ~50x50 micron region within the center of the window from any rotational orientation.

These EDX calibration standards were developed in partnership with Dr. Nestor J. Zaluzec from the Electron Microscopy Center and the Center for Nanoscale Materials at Argonne National Laboratory.

Applications

- Detector energy axis and energy resolution calibration
- Detector Window Transmission Evaluation
- Detector solid angle measurements
- Electron optical instrument system peak measurements
- Specimen holder penumbra measurements

Specifications

20 nm thick germanium (Ge) coating on microporous 20 nm thick, low-stress silicon nitride (SiN)

Two micron pores on 1:1 pitch grid pattern

100 micron thick frame, fits 3 mm sample holders

(1) 500 x 500 micron window

Citations

Zaluzec NJ, DesOrmeaux JP, and Roussie J. A Ge/SiNx Standard for Evaluating the Performance of X-ray Detectors in the SEM, S/TEM and AEM. *Microscopy and Microanalysis*, 22(S3): 322-323.

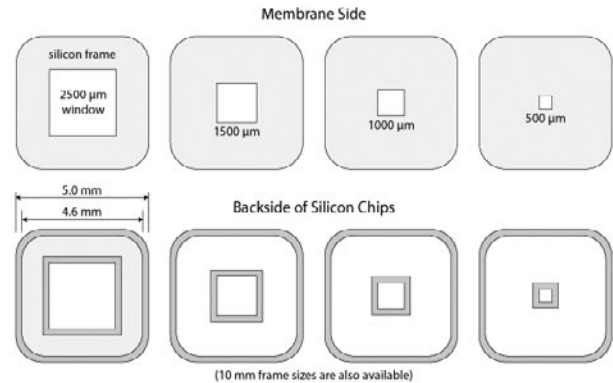
Zaluzec NJ, Wen J, Wang J, and Miller DJ. Quantitative Measurements of the Penumbra of XEDS Systems in an AEM. *Microscopy and*

Ordering Information

Cat No.	Description	Qty.
76042-01	EDX-XEDS TEM Window Grid	5/pk

X-Ray Windows, Square Frame

Ideal substrates for x-ray microscopy and x-ray spectroscopy techniques.



State-of-the-art manufacturing and expert engineering allow for competitive prices of these windows. Made in the USA, these X-Ray windows are entirely plasma cleanable to remove organic contamination.

Flat, uniformly deposited films provide consistent backgrounds with low field-to-field variability and high x-ray transmission.

Available in two membrane types:

Silicon Nitride: Low-stress LPCVD Silicon Nitride membranes are mechanically strong and well-suited for high temperature and differential pressure environments

G-FLAT™ Silicon Oxide: Proprietary wrinkle-free G-FLAT™ Silicon Oxide membranes are well-suited for correlative optical and x-ray microscopy and analyses requiring a nitrogen-free background

These membranes are ideally suited for biological imaging studies, with a glass-like hydrophilic surface.

Ordering Information

G-FLAT™ Silicon Oxide X-Ray Windows

- 310 micron thick frame
- Unique G-Flat™ wrinkle-free Silicon Oxide film
- Compatible with ultra-high vacuum (UHV) applications (300nm Membrane)
- Non-Porous

Cat. No.	Description	Window (Dim Sq.)	Membrane (Thickness)	Qty.
76042-10	G-FLAT™ SiO X-Ray Window	500µm	100nm	20/pk
76042-11	G-FLAT™ SiO X-Ray Window	500µm	300nm	20/pk

Silicon Nitride X-Ray Windows

- 320 micron thick frame
- LPCVD silicon nitride film
- Low-Stress ~200 MPa
- Non-Porous

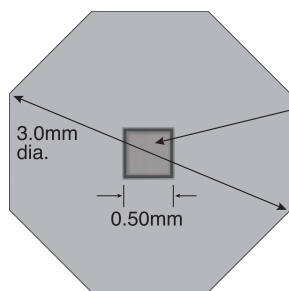
Cat. No.	Description	Window (Dim Sq.)	Membrane (Thickness)	Qty.
76042-12	Silicon Nitride X-Ray Window	500µm	50nm	20/pk
76042-13	Silicon Nitride X-Ray Window	1000µm	50nm	20/pk
76042-14	Silicon Nitride X-Ray Window	500µm	100nm	20/pk
76042-15	Silicon Nitride X-Ray Window	1000µm	100nm	20/pk
76042-16	Silicon Nitride X-Ray Window	1500µm	200nm	20/pk
76042-17	Silicon Nitride X-Ray Window	2500µm	200nm	20/pk

III Holey Silicon Nitride TEM Window Grids

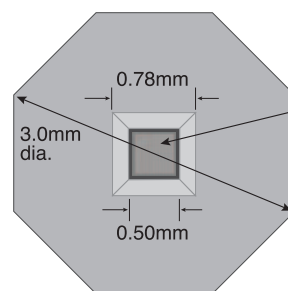
State-of-the-art support film.

This latest addition to our line of TEM Window Grids is manufactured using advanced MEMS technology to produce a unique 500 x 500 micrometer aperture with 200nm low-stress silicon nitride membrane.

Available with square holey pattern or 5 x 5 indexed array with hexagonal holey film.



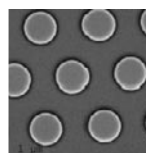
Front Side



Back Side

Features

- Resistant to acids, bases, and solvents.
- Can be easily plasma-cleaned to remove organic contamination.
- Tolerate high-temperature experiments and imaging up to 1000°C.
- Provide a carbon-free background.
- Packaged under cleanroom conditions.



500nm nanopores

Specifications

Membrane Thickness	200nm
Window Size	0.5 x 0.5mm
Frame Thickness	200µm

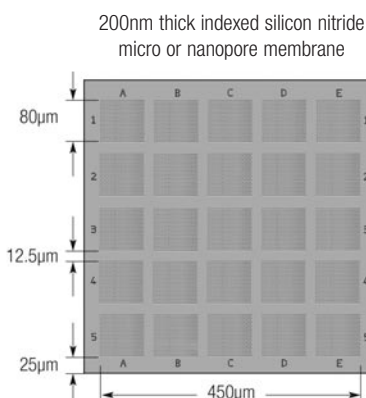
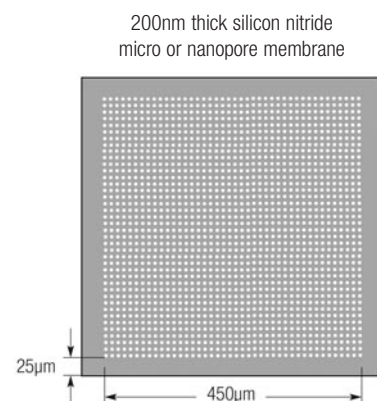
Square Pattern on 200nm Silicon Nitride

Cat No.	Hole Size	Layout	Total No.	Pitch	Porosity	Qty.
Microporous						
76043-40	10.0µm	22 x 22	484	20.0µm	22.8%	10/pk
76043-41	5.0µm	45 x 45	2,025	10.0µm	22.8%	10/pk
76043-42	2.5µm	90 x 90	8,100	5.0µm	22.8%	10/pk
76043-43	2.0µm*	150 x 150	22,500	3.0µm	22.8%	10/pk
76043-44	1.2µm‡	180 x 180	32,400	2.5µm	22.8%	10/pk
76043-45	1.0µm	225 x 225	50,625	2.0µm	22.8%	10/pk
Nanoporous						
76043-50	750nm	300 x 300	90,000	1.5µm	22.3%	10/pk
76043-51	500nm	450 x 450	202,500	1.0µm	22.3%	10/pk
76043-52	400nm	562 x 562	315,844	0.8µm	22.8%	10/pk
76043-53	300nm	750 x 750	562,500	0.6µm	22.3%	10/pk
76043-54	250nm	900 x 900	810,000	0.5µm	22.3%	10/pk
76043-55	200nm	1125 x 1125	1,265,625	0.4µm	22.8%	10/pk
76043-56	150nm	1125 x 1125	1,265,625	0.4µm	22.4%	10/pk
76043-57	100nm	1125 x 1125	1,265,625	0.4µm	22.1%	10/pk

Indexed Hexagonal Pattern

Cat No.	Hole Size	Layout	Total No.	Pitch	Porosity	Qty.
Microporous						
76043-60	10.0µm	4 x 4 x 25	400	20.0µm	22.8%	10/pk
76043-61	5.0µm	8 x 8 x 25	1,600	10.0µm	22.8%	10/pk
76043-62	2.5µm	16 x 16 x 25	6,400	5.0µm	22.8%	10/pk
76043-63	2.0µm*	25 x 25 x 25	15,625	3.0µm	22.8%	10/pk
76043-64	1.2µm‡	32 x 32 x 25	25,600	2.5µm	22.8%	10/pk
76043-65	1.0µm	40 x 40 x 25	40,000	2.0µm	22.8%	10/pk
Nanoporous						
76043-70	750nm	50 x 50 x 25	62,500	1.5µm	22.3%	10/pk
76043-71	500nm	80 x 80 x 25	160,000	1.0µm	22.3%	10/pk
76043-72	400nm	100 x 100 x 25	250,000	0.8µm	22.8%	10/pk
76043-73	300nm	130 x 130 x 25	422,500	0.6µm	22.3%	10/pk
76043-74	250nm	160 x 160 x 25	640,000	0.5µm	22.3%	10/pk
76043-75	200nm	200 x 200 x 25	1,000,000	0.4µm	22.8%	10/pk
76043-76	150nm	200 x 200 x 25	1,000,000	0.4µm	22.4%	10/pk
76043-77	100nm	200 x 200 x 25	1,000,000	0.4µm	22.1%	10/pk

* R2/1 equivalent ‡ R1.2/1.3 equivalent



TEM WINDOW GRIDS

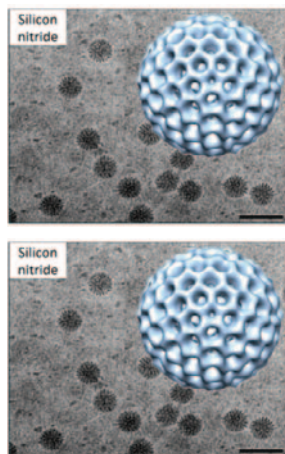
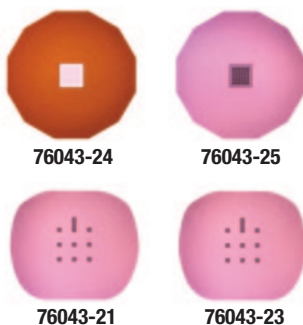
III Cryo-SiN

An ideal substrate for cryo-microscopy.

- Avoid substrate degradation seen with carbon grids.
- Plasma cleanable to reduce contaminants.
- Our proprietary carbon coating may also improve charge dissipation leading to a reduction in beam induced movement.
- Large 500 µm windows provide ~50 x 50 µm viewing from any orientation at 70 degrees of tilt for tomography.

"Our initial findings indicate that viral particles prepared on Cryo-SiN, exhibited greater contrast in comparison to those prepared on holey carbon films under the same conditions. As a result, we were able to calculate 3D reconstructions of viral particles prepared on Cryo-SiN using a fraction of the images required for samples prepared on holey carbon films."

Tanner et al. Microscopy & Microanalysis Abstract, 2013



Ordering Information

Cat. No.	Description	Qty
76043-21	Silicon Nitride 20 nm thick TEM Windows (9 Windows)	each
76043-22	Silicon Nitride 20 nm thick TEM Windows - Single 500 micron window	each
76043-23	Silicon Nitride 10 nm thick TEM Windows (9 Windows)	each
76043-24	Silicon Nitride 50 nm thick Microporous (Single 500 micron window)	each
76043-25	Silicon Nitride 20 nm thick Microporous (Single 500 micron window)	each

III Silicon Nitride Lift-Out TEM Windows

Low-stress silicon nitride for lift-out applications

Available with or without gold contacts.

State Of The Art — Our expert engineering and MEMS fabrication processes allow us to provide these one of a kind silicon nitride lift-out grids.

Open Half-Grid Shape — Our Silicon Nitride Lift-Out TEM Windows feature a large, robust window with a freely suspended side along one length of the window, providing an easily accessed edge for sample preparation and thinning to electron transparency (e.g. 50 nm or less).

Ready To Use Gold Contacts — 200 nm thick gold contacts for sample electrical biasing or heating are formatted for FIB-based sample preparation methods.

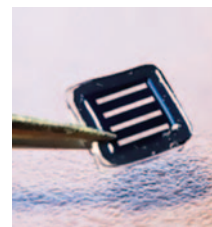


Cat. No.	Description	Pack
76043-01	Silicon Nitride Lift-Out TEM Windows with gold contacts	each
76043-02	Silicon Nitride Lift-Out TEM Windows	each

III Porous Membrane Chips

Nanoporous, Microporous and Microslit.

Our Porous Membrane Chips are available in a range of membrane types and pore sizes and shapes to suit a variety of applications.



4-slot Membrane Chip

Nanoporous Silicon Nitride — Proprietary membranes that are 100 nm thick that have average 50 nm diameter pores and 20% porosity, with one, two or four membrane/chip formats, with high-resolution imaging and separation properties.

Microporous Silicon Nitride — Robust membranes that are 400 nm thick and have either 0.5, 3 or 8 µm diameter pores and high (20%) porosity, suitable for more demanding applications.

Microslit Silicon Nitride — Novel rectangular prism-shaped pores in robust 400 nm thick silicon nitride membranes with 10% porosity, suitable for separation applications.

G-FLAT™ Silicon Oxide — Proprietary and optically transparent membranes for high-resolution imaging applications, available with either 0.5, 3, 5 or 8 µm diameter pores and low (5%) or high (20%) porosity.

Plasma Compatible — All of our Porous Membrane Chips can be treated with oxygen or oxygen-argon plasma for surface activation and/or removal of any organic contamination.

Device Integration — Our Porous Membrane Chips can be easily integrated into microfluidic-type applications where suspension of materials of interest across a permeable and transparent membrane is desired.

Ultrathin Membranes — Flat, uniformly deposited films and 100 nm to 400 nm thick suspended membranes provide consistent backgrounds with low field-to-field variability and high optical transparency.

Ordering Information

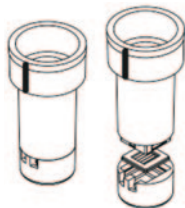
Cat. No.	Description	Qty
76043-09	Microporous G-Flat 3.0 micron Membrane Chips (Low Porosity)	each
76043-11	Microporous G-Flat 0.5 micron Membrane Chips (High Porosity)	each
76043-12	Microslit Silicon Nitride 8.0 micron Membrane Chips	each
76043-13	Microslit Silicon Nitride 1.0 micron Membrane Chips	each
76043-14	Microslit Silicon Nitride 0.5 micron Membrane Chips	each
76043-15	Microporous Silicon Nitride 8.0 micron Membrane Chips (High Porosity)	each
76043-16	Microporous Silicon Nitride 3.0 micron Membrane Chips (High Porosity)	each
76043-17	Microporous Silicon Nitride 0.50 micron Membrane Chips (High Porosity)	each
76043-18	Nanoporous Silicon Nitride 100 nm thick Membrane Chips (4 slot)	each
76043-19	Nanoporous Silicon Nitride 100 nm thick Membrane Chips (2 slot)	each
76043-20	Nanoporous Silicon Nitride 100 nm thick Membrane Chips (1 slot)	each

III SepCon® Spin Vials for Particle Separation & Concentration

NanoPorous and Microslit Membranes for high resolution imaging.

Features

- Ability to capture particles of different sizes, either nanoparticles with 45 nm pores or microparticles and cells with 0.5 and 1 µm microslits.
- Easy-to-follow protocol using standard microcentrifuges, with 5 to 20 minute processing times.
- Porous Membrane Chips that are easily removed from spin columns for high-resolution optical and electron microscopy imaging



Clean-up particle preparations and easily image captured materials that remain on highly transparent and ultrathin membrane.

Capture Multiple Particles

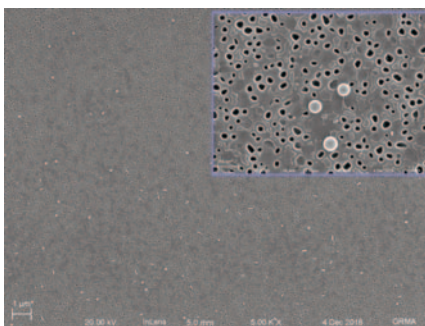
- NanoPorous Chips: pore size is 45 nm
- Microslits: slit sizes of either 0.5 or 1 µm
- Capture a range of microparticles and cells

Save Time

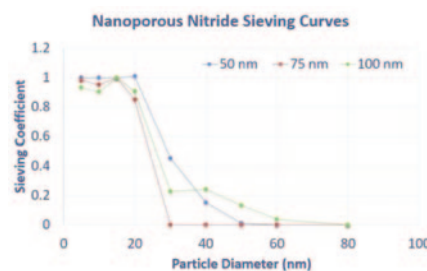
- 5 to 20-minute processing time
- Easy to follow protocol using SepCon Spin Vials and standard Microcentrifuge

Porous Membrane Chips

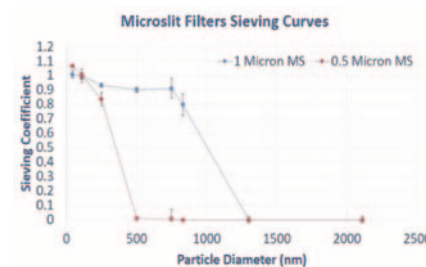
- Easily remove membrane chips for high-resolution optical and electron microscopy imaging



NanoPorous Silicon Nitride



Silicon Nitride Microslits



Ordering Information

Cat. No.	Description	Qty
76042-20	SepCon Spin Vial, Nanoporous	6/pk
76042-21	SepCon Spin Vial, Nanoporous	12/pk
76042-22	SepCon Spin Vial, 0.5 micron Microslit	6/pk
76042-23	SepCon Spin Vial, 0.5 micron Microslit	12/pk
76042-24	SepCon Spin Vial, 1.0 micron Microslit	6/pk
76042-25	SepCon Spin Vial, 1.0 micron Microslit	12/pk

Physical Properties

Membrane Composition	Silicon Nitride (SiN)
Thickness	400 nm
Pore Size Cut-Off	500, 1000 nm
Porosity	10% (500 nm), 16% (1000 nm)
Surface Charge	Neutral to slightly negative
Tube & Vial Material	High-density Polypropylene
Gasket Material	Platinum-cured Silicone, USP VI

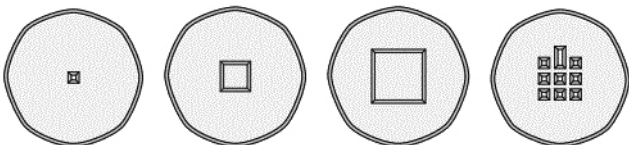
Physical Properties

Membrane Composition	Silicon Nitride (SiN)
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Porosity	10% (500 nm), 16% (1000 nm)
Surface Charge	Neutral to slightly negative
Tube & Vial Material	High-density Polypropylene
Gasket Material	Platinum-cured Silicone, USP VI

TEM WINDOW GRIDS

III Silicon Nitride TEM Window Grids

Silicon Nitride TEM Window Grids perform well under harsh lab conditions.



Silicon frames are 100µm thick. Grids fit standard 3mm holders and most double tilt holders. They come in clear gel-boxes for simpler sample preparation.

Features

- **Plasma Cleanable** — can be vigorously plasma cleaned to remove organic contamination
- **Field to Field Uniformity** — Less than 0.5 nm variation in film thickness across an entire production log, not just a single window grid
- **Tolerates temperatures above 1000°C** — Supports use in environmental TEMs where dynamic processes are observed at high temperatures
- **Withstands Harsh Conditions** — Provides an ideal balance of imaging resolution, chemical stability and mechanical strength
- **Incorporates LPCVD, low-stress (~250MPa), non-stoichiometric silicon nitride** — Provides flat, insulating and hydrophobic surfaces

Recommended Use

High Resolution Imaging:	5nm	76042-43 , 1 square (25x25µm) 76042-44 , 9 squares (50x50µm) 76042-45 , 2 slots (50x1500µm)*
Robust, Increased High Resolution:	10nm	76042-46 , 9 squares (100x100µm)
Everyday Imaging:	20nm	76042-49 , 1 square (500x500µm) 76042-50 , 9 squares (100x100µm)
Demanding Conditions:	50nm	76042-53 , 1 square (100x100µm) 76042-52 , 1 square (500x500µm) 76042-51 , 1 square (1000x1000µm) 76042-50 , 9 squares (100x100µm)
Materials & Cryo-EM Suspension:	Microporous	76042-41 , 1 square (500x500µm) 76042-40 , 1 square (500x500µm)

*Coated with 1 nm of ultrahigh purity carbon to minimize charging

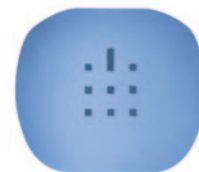
Ordering Information

Cat. No	Window(s) (Dim.)	SiN (Th)	Qty
Silicon Nitride Microporous TEM Window Grids (2.0 µm pores with labeled grid)			
76042-40	500µm sq.	20nm	10/pk
76042-41	500µm sq.	50nm	10/pk
Silicon Nitride Nanoporous TEM Window Grid			
76042-42	500µm sq.	20nm	10/pk
Silicon Nitride TEM Window Grids			
76042-43	25µm sq.	5nm	10/pk
76042-44	(8) 50µm sq., (1) 50x100µm	5nm	10/pk
76042-45	(2) 50x1500µm	5nm	10/pk
76042-46	(8) 100 sq., (1) 100x350µm	10nm	10/pk
76042-47	(8) 250 sq., (1) 250x500µm	10nm	10/pk
76042-48	(8) 100 sq., (1) 100x350µm	20nm	10/pk
76042-49	500µm sq.	20nm	10/pk
76042-50	(9) 100µm sq.	50nm	10/pk
76042-51	1000µm sq.	50nm	10/pk
76042-52	500µm sq.	50nm	10/pk
76042-53	100µm sq.	50nm	10/pk

III Silicon Dioxide TEM Window Grids

Engineered to be easier to handle.

By making the grids slightly narrower users now have easy access to grids in TEM holders. No more fumbling with tweezers while trying to pick up or put down grids. The new TEM Window grid shape is still compatible with all standard holders. TEM Window dimensions are 2.9mm in diameter and 100µm thick.



Features

- **Plasma Cleanable** — Can be vigorously plasma cleaned to remove organic contamination
- **Field to Field Uniformity** — Reduced variability
- **Tolerates temperatures above 1000°C** — Supports use in environmental TEMs where dynamic processes are observed at high temperatures
- **Withstands Harsh Conditions** — Provides an ideal balance of imaging resolution, chemical stability and mechanical strength
- **Incorporates stoichiometric silicon dioxide** — Offers the ability to analyze for nitrogen by EDX techniques

Specifications

100 micron thick frame, fits 3 mm sample holders

Non-Porous films are lightly wrinkled with approximately 5 microns or less deflection across 100 microns of travel. This is typically not problematic for high-resolution imaging.

GFLAT silicon oxide films are created by a proprietary process that uniquely results in flat, suspended silicon oxide membranes. These membranes are ideally suited for biological imaging studies, with a glass-like hydrophilic surface. These TEM Windows are essentially micro-scale glass cover slips.

Ordering Information

Cat. No	Window(s)(Dim.)	SiO ₂ (Th)	Qty
Non-Porous Silicon Dioxide TEM Windows			
76042-90	(8) 100µm, (1) 100x350µm	40nm	10/pk
76042-91	(8) 50µm, (1) 50x100µm	20nm	10/pk
Non-Porous Silicon Dioxide G-FLAT Window			
76042-92	1000µm sq.	100nm	10/pk

III Silicon Apertures

No-membrane frames

Our Silicon Apertures feature the same TEM window grid-style chip size but lack any suspended membrane so that there is a freely accessible opening through the chip frame.

Features

Background-free Imaging — Open apertures for free suspension of materials so that they can be imaged without intervening membranes

Plasma Cleanable — Silicon apertures can be vigorously plasma cleaned to remove organic contamination

Silicon Composition — Chip frames comprise P-type doped silicon

Cat. No.	Description	Qty
76043-03	Aperture Grid w/single 50 micron square	each
76043-04	Aperture Grid w/single 100 micron square	each
76043-05	Aperture Grid w/single 500 micron square	each

III Pure Silicon TEM Windows

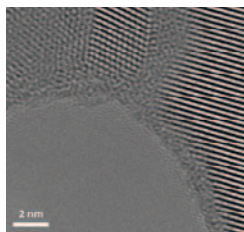
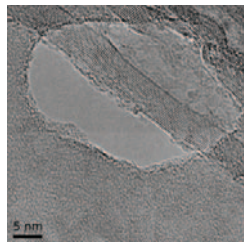
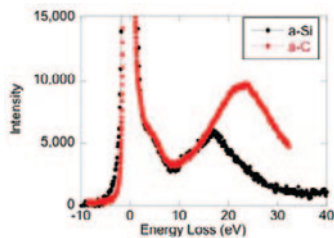
Pure Silicon sets these TEM windows apart from the rest

5nm, 9nm, 15nm, 35nm

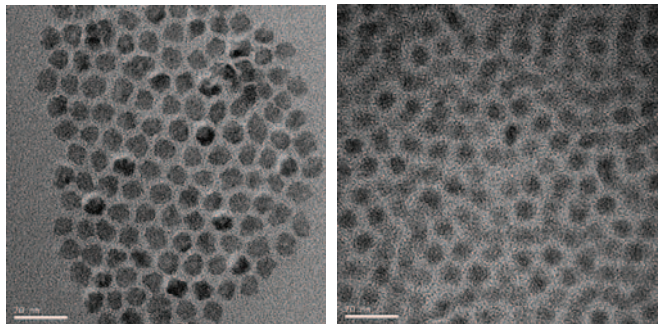


Features

- Nanometer Thinness** — Pure Silicon TEM Windows feature imaging windows with 5 to 35nm thickness, reducing background contribution and interference for higher contrast imaging. Most impressively, 5nm thick Non-Porous Pure Silicon TEM Windows are thinner than the thinnest commercially available amorphous carbon membranes.
- Plasma Cleanable** — can be vigorously plasma cleaned to remove organic contamination, unlike traditional carbon grids
- Field to Field Uniformity** — Non-Porous Pure Silicon TEM Windows are more consistently thin than carbon grids, reducing field-to-field variability. (Note: Porous windows do have inherent crystalline features, but feature background-free nanometer-scale pores).
- Reduced Chromatic Blur** — In comparison to the thinnest commercially available amorphous carbon membranes, 5 nm Non-Porous Pure Silicon TEM Windows yield half the chromatic blur. This dramatic difference results from a two-fold reduction in inelastic scattering of electrons passing through the thinner membranes of Silicon TEM Windows. In turn, the reduced chromatic blur offers a potential two-fold improvement in imaging resolution.
- Nanometer-Scale Pores** — Pure Silicon TEM Windows are available as porous films with pores ranging from 5 to 50 nm in diameter. The pores allow simple and stable suspension of nanoscale materials for imaging without intervening background.
- Silicon Composition** — The elemental silicon composition of TEM Windows remarkably increases stability at high beam currents and at high annealing temperatures. The Pure Silicon composition also introduces a minimal background signal, making elemental analyses of sample containing nitrogen and/or carbon possible by EDX and EELS.
- Isolated Poly-Crystallinity** — The polycrystalline nature of porous Pure Silicon TEM Windows offers an internal calibration standard for x-ray diffraction studies. The isolated crystalline features also provides a convenient and reliable scale for high-resolution size measurements, well-characterized crystal lattice of silicon.
- Hydrophilicity** — The hydrophilicity of both non-porous and porous Pure Silicon TEM Windows is tunable by plasma and/or ozone treatment making sample preparation easier, particularly for samples in aqueous solutions.



- Increased Stability** — At high beam currents and high annealing temperatures (600°C for non-porous, >1000°C for nanoporous)
- Silicon Composition** — Sputter-deposited, pure, intrinsic silicon
- Minimal Background Signal** — Enables elemental analyses of samples containing nitrogen and/or carbon



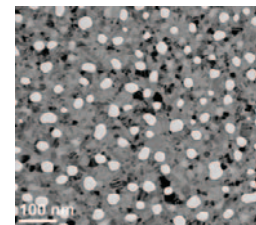
Lead Selenide nanoparticles on 5 nm non-porous Pure Silicon TEM Window (left) and conventional carbon film (right). Particles provided by Chris Evans, University of Rochester and imaged by Brian McIntyre, University of Rochester.

Options

Nanoporous — Using P30 membranes has made the Nanoporous TEM windows significantly more porous. Pore sizes have increased to include a range of pores from 10-60 nanometers in diameter.

Single Crystal — with $\langle 1-0-0 \rangle$ orientation, offers a very thin 35nm membranes for diffraction studies and other applications requiring uniform background from a single crystal film.

Non-porous — Non-Porous films are lightly wrinkled with approximately 5 microns or less deflection across 100 microns of travel. This is typically not problematic for high-resolution imaging.



Nanoporous Low-resolution TEM image of a new P30 Nanoporous TEM Window

Ordering Information

Cat. No	Window(s) (Dim.)	Si (Th)	Qty
Non-Porous Pure Si TEM Windows			
76042-71	25µm sq.	5nm	10/pk
76042-72	(8) 50µm sq., (1) 50x100µm	5nm	10/pk
76042-73	(2) 50x1500µm	5nm	10/pk
76042-74	(8) 100 sq., (1) 100x350µm	9nm	10/pk
76042-75	(2) 100x1500µm	9nm	10/pk
76042-76	(8) 100 sq., (1) 100x350µm	15nm	10/pk
76042-77	(2) 100x1500µm	15nm	10/pk

LIQUID TEM

Wet "Liquid" TEM Kit

Why K-kit?

K-kit meets all needs for Liquid TEM

1 Native State in Liquid

- Available with undiluted solution.
- Preserve the original morphology and physical state in liquid

2 In-situ Observation

- Kinetic mechanism of metal growth or physicochemical reaction process in liquid can be in-situ observed with increased reaction time.

3 Quantitative Analysis

- Software of image recognition for nanoparticle size distribution analysis.

4 Compatible with Versatile Microscopy Analyses

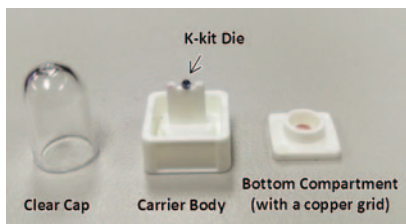
- Applicable to TEM, FIB, and STEM.
- Available for EDX analysis.
- High resistance to most chemicals.
- Working temperature range from -40°C to 120°C.

Patents being issued and publication:

US 7807979 B2

US 8969827 B2

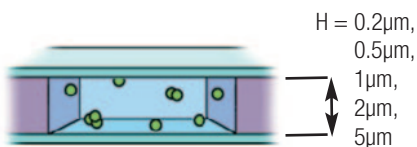
Anal. Chem.2012, 84: 6312-6316



Dimensions

Window Length: 300µm, Width 25µm

Channel Height (H): 0.2 and 2.0 standard
0.5, 1.0 and 5.0 available



III K-kit

A Specimen Holder for Liquid Sample Analysis in TEM

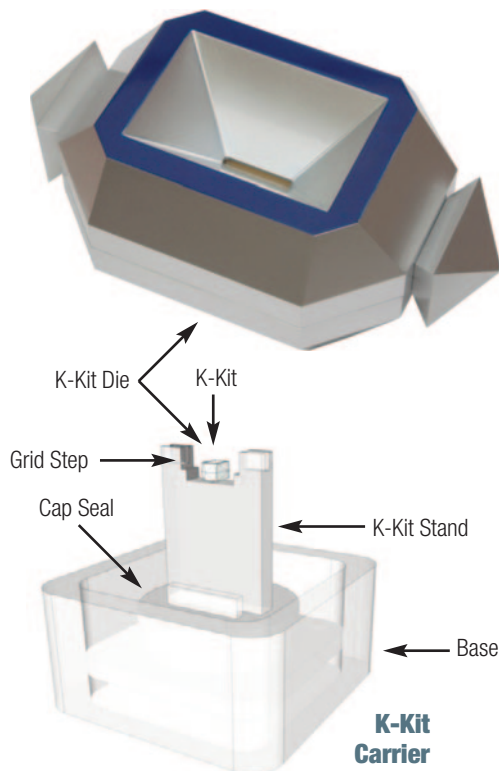
Overview

K-kits are sample holders designed to facilitate convenient TEM observation of liquid samples, allowing nano-objects, aggregates, and agglomerates (NOAAs) in liquid samples to be characterized.

With vacuum compatible sealing of liquids in electron-transmitting thickness, K-kits are micro reaction chambers for countless experiments in materials, chemical, and biological research.

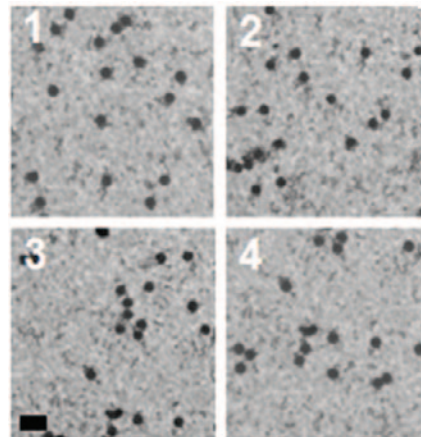
Features

- Applicable for most TEM holder brands
- Strong structural reliability under vacuum
- Sealing glue compatible to many solvents
- Disposable
- Free of cross-contamination
- Easy to use

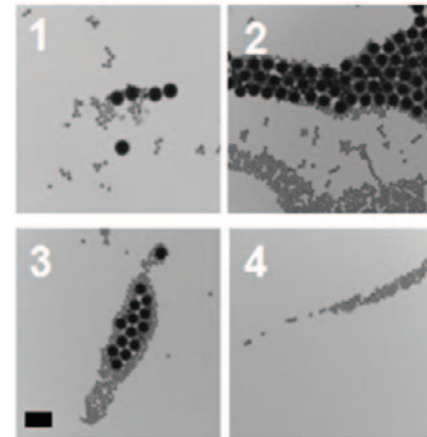


Sample Analysis Comparison

K-kit original physical state



Conventional aggregated after drying



Images shown: NIST traceable polystyrene beads. Scale Bar 500nm.

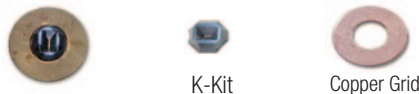
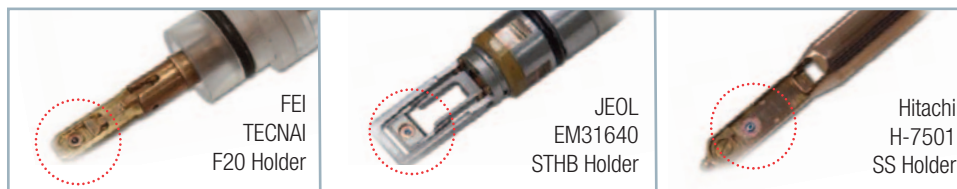
Physicochemical Parameters	K-kit	Conventional
Composition	✓	✓
Size	✓	✓
Shape	✓	✓
Size Distribution	✓	Δ
Aggregation and Agglomeration in liquid	✓	✗
Particle Concentration	✓	✗
Liquid TEM Observation	✓	✗

✓ = Good Δ = Case Dependent ✗ = Not Available

Wet "Liquid" TEM Kit (continued)

K-kit Adaptability

Compatible with all kinds of TEM Holders



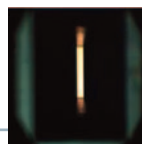
Strong Structural Reliability under Vacuum

Silicon Body (MEMS technology): Use a Si-based structure, ensuring strength and reliability. (MEMS, Micro-Electro-Mechanical Systems)

Torr Seal® Epoxy: A trusted and widely-used glue, suitable for high-vacuum systems. (Torr Seal®, a trade mark owned by Agilent Tech. Inc.)



Silicon Nitride Observation Window: Material intrinsically tough, durable to withstand drastic pressure changes.



Sealing glue compatible with many solvents

The following table shows the test results of Torr Seal Epoxy soaked in chemical solvents for 24 hours and then examined using FTIR (if dissolved), and visual observation (if dispersed).

	Water	PEG400	DMSO	Ethanol	0.1N HCl	0.1N KOH
Compatibility (FTIR)	✓	✓	✓	✓	✓	✓
	Hexane	IPA	Methanol	DCM	THF	Acetone
Compatibility (FTIR)	✓	✓	✓	X	X	X

(FTIR, Fourier Transform Infrared Spectroscopy) ✓ = Compatible (FTIR not detected) X = Use with care (FTIR detected)

Wet and Thin Layer Mode of K-kit

The K-kit can be used in either Wet Mode or Thin Layer Mode.

Wet Mode: The loaded liquid sample is sealed and imaged using TEM in the native liquid environment.

Thin Layer Mode: A patented liquid drying protocol preserves the original morphology and physical state of nanomaterials with improved imaging resolution.

Sample Preparation	Wet Mode	Thin Layer Mode
Inner Status of K-kit	With Liquid 	Dried
Imaging Resolution	Good	Excellent
Gap Size (Considered)	300~500nm	2000~3000nm
Particle Size (Loadable)	10nm~300nm	3nm~2000nm
Particle Shape	Keeping original	Potentially, could be deformed.
Chemical Reduction or Potential Damage by Electron Energy	High	Low
Possible States of K-kit	Liquid fully filled	Thin liquid layer on wall
	Liquid partially filled	Dry state

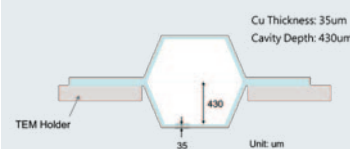
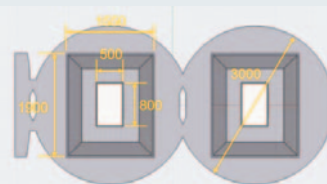
Now Liquid TEM is even easier...

III K-kit Folding Grids

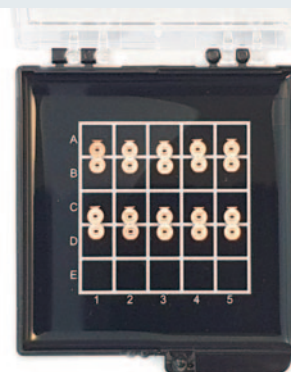


Streamline your preparation of liquid TEM samples with this new folding grid developed specifically for the K-kit. This low-cost single-use option eliminates the gluing and levelling steps required with a standard copper grid.

Dimensions



Ordering Information



Cat. No.	Description	Qty.
K7273	K-kit Folding Grids	10/pk

LIQUID TEM

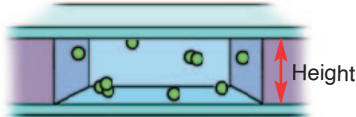
Wet "Liquid" TEM Kit (continued)

K-kit Components

- Tools are optional available in a Tool Set or ordered individually. The glues are also available.
- Figures are for illustration purposes. The tools you order may be different in color and/or from minor design changes.

K-kits

Six gap heights (H) available:
 0.2µm or 2µm are standard,
 0.1µm, 0.5µm, 1.0µm and
 5.0µm sizes are also available.



Two membrane SiN thicknesses available: 100nm (standard) and 30nm (thin)

Three package options: 4 or 6 K-kits per pack, or a Tool Box.

Cat No.	Description	SiN Thickness	Qty.
Standard Sizes			
K7260-402	K-kit 0.2	100nm	4/pk
K7261-402		30nm	4/pk
K7260-420	K-kit 2.0	100nm	4/pk
K7261-420		30nm	4/pk
K7260-602	K-kit 0.2	100nm	6/pk
K7261-602		30nm	6/pk
K7260-620	K-kit 2.0	100nm	6/pk
K7261-620		30nm	6/pk

K-kit Tool Box

The K-kit Tool box houses a full tool set, including K-kit holder, Sample Loading Stage, Needle Pen, Gluing Stand, Channel Opener, Sealing Glue, Mounting Glue, Glass Slides, 6/pk of K-kits, Shipping Box (empty), and some replacement parts.

Also available with everything except the K-kits.

Cat No.	Description	SiN Thickness	Qty.
K-kit Tool Box, 2.0 µm, includes full tool set			
K7261-R	Silver	100nm	each
K7261-T	Silver	30nm	each
K7261-V	Vermilion	100nm	each
K7261-X	Vermilion	30nm	each
K-kit Tool Box, 0.2 µm, includes full tool set			
K7261-S	Silver	100nm	each
K7261-U	Silver	30nm	each
K7261-W	Vermilion	100nm	each
K7261-Y	Vermilion	30nm	each

Additional Sizes/Quantities

K7260-401	K-kit 0.1	100nm	4/pk
K7261-401		30nm	4/pk
K7260-601	K-kit 0.1	100nm	6/pk
K7261-601		30nm	6/pk
K7260-405	K-kit 0.5	100nm	4/pk
K7260-605		100nm	6/pk
K7260-410	K-kit 1.0	100nm	4/pk
K7260-610		100nm	6/pk
K7260-450	K-kit 5.0	100nm	4/pk
K7260-650		100nm	6/pk

K-kit Tool Box, 0.1 µm, includes full tool set

K7260-K01	Silver	100nm	each
K7261-K01	Silver	30nm	each
K7260-V01	Vermilion	100nm	each
K7261-V01	Vermilion	30nm	each



Cat No.	Description	SiN Thickness	Qty.
K-kit Tool Box, 0.5 µm, includes full tool set			
K7260-K05	Silver	100nm	each
K7260-V05	Vermilion	100nm	each
K-kit Tool Box, 1.0 µm, includes full tool set			
K7260-K10	Silver	100nm	each
K7260-V10	Vermilion	100nm	each
K-kit Tool Box, 5.0 µm, includes full tool set			
K7260-K50	Silver	100nm	each
K7260-V50	Vermilion	100nm	each
K-kit Tool Box, excludes K-Kits			
K7261	Silver		each
K7262	Vermilion		each

Wet "Liquid" TEM Kit (continued)

K-kit Accessories

NEW ■■■ K-kit Folding Grids, see page 67

■■■ K-kit Holder

The K-kit Holder consists of an anodized aluminum header and a stainless steel handle. The K-kit carrier fits on the header (after removing the bottom compartment). When the notch on the side of the header fits over the horizontal bar on the Loading Stage (see below), the K-kit on the carrier attached on the header will be just above the liquid sample.

Cat. No.	Description	Qty.
K7263	K-kit Holder	each

■■■ Needle Pen

The Needle Pen is designed to facilitate the K-kit gluing operation. It has a thin needle 3.0 mm long and 0.27 mm in diameter. The thin needle makes it convenient to pick just enough glue (of the order of 0.1 $\mu\text{l}^{(6)}$) for sealing the channel openings and (around 1 $\mu\text{l}^{(6)}$) for mounting the copper grid. The needle is made of stainless steel. It is strong, yet slightly flexible, suitable for the job.

Notes:

It is important to keep the needle free of residue glue. Please wipe the needle clean right after each use. It will be practically impossible to clean the needle once residue glue on it cures.

The needle is held in place in the pen by a set screw on the side of the pen. A replacement needle and a small Allen key are provided with each Needle Pen. The needle is sharp. Please handle with care.

Cat. No.	Description	Qty.
K7265	Needle Pen	each

■■■ Sample-Loading Stage

The Loading Stage consists of an anodized aluminum body. It has a horizontal bar in a recess on the side and a hole in the middle to house the Liquid Stage, which is a removable stainless steel rod. The removable design is for easy cleaning. The horizontal bar defines the rotational axis for the K-kit Holder, which has a notch on the header to fit on the horizontal bar.

Cat. No.	Description	Qty.
K7264	Sample Loading Stage	each

■■■ Gluing Stand

The Gluing Stand has a stainless steel base and an anodized aluminum header, which is much like the header on the K-kit holder, without the notch on the side. The Gluing Stand keeps the K-kit carrier in place for gluing work.

Cat. No.	Description	Qty.
K7266	Gluing Stand	each

■■■ Channel Opener

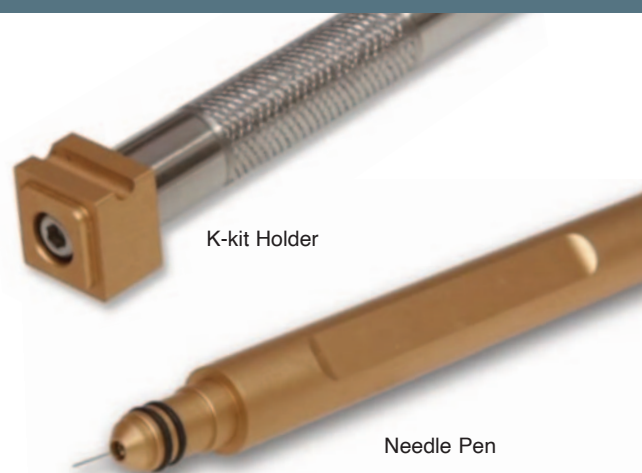
The Channel Opener is used to remove the channel tips, while the K-kit stays on the carrier. It's made of anodized aluminum with a cut-off slot design at one end.

Cat. No.	Description	Qty.
K7269	Channel Opener	each

■■■ Copper Grids

Ten pieces of Copper Grid per pack.

Cat. No.	Description	Qty.
K7270	Copper Grid	10/pk



K-kit Holder

Needle Pen

■■■ Accessory Box

The Accessory Box contains sealing and mounting glues, four plastic sticks, and spare parts, including a spare needle, an Allen key for the Needle Pen, a Channel Opener, and two Liquid Stages. (The label can be redesigned.)



Cat. No.	Description	Qty.
K7267	Accessory Box	each

■■■ Starter Box

The Starter Box contains all of the essentials for K-kit loading. It consists of glues, a beaker, four stirring sticks, and two stainless steel thin needles.



Cat. No.	Description	Qty.
K7268	Starter Box	each

■■■ Glue Box

The Glue Box contains sealing and mounting glues and stirring sticks.

Notes: Glue capsules will now have a tin foil seal on the bottle mouth for shipping. Sometimes during shipping, the glue could become stained and dried on the cap or bottle mouth of the capsule. Sometimes, the Torr Seal glue will have a thin oil-like layer on the surface. This will not affect anything and is normal. Please stir first to mix evenly.



Cat. No.	Description	Qty.
K7272	Glue Box	each

■■■ Slide-Glass Pack

Six glass slides per pack.



Cat. No.	Description	Qty.
K7271	Slide-Glass Pack	6/pk

TEM HOLDERS

JEOL 2-Position Single Tilt Holder



A single tilt two-grid sample holder. Grids are held in place by easy to remove circlips. Comes complete with loading stand, circlip extraction tool, and is supplied in its own mahogany box.

Cat. No.	Description	Qty.
EMS017	JEOL 2-Position Single Tilt Holder	each

JEOL 2-Position Single Tilt Multi-Sample Holder



A single tilt multi-grid holder. Will accommodate 6 grids with an easy click stop reproducible movement between each specimen. It is ideal for scanning through serial sections or for comparing against a standard.

Grids are held in place by easy to remove circlips. Comes complete with loading stand, circlip extraction tool, and is supplied in its own mahogany box.

Cat. No.	Description	Qty.
EMS027	JEOL 2-Position Single Tilt Holder	each

JEOL 3-Position Grid Insert

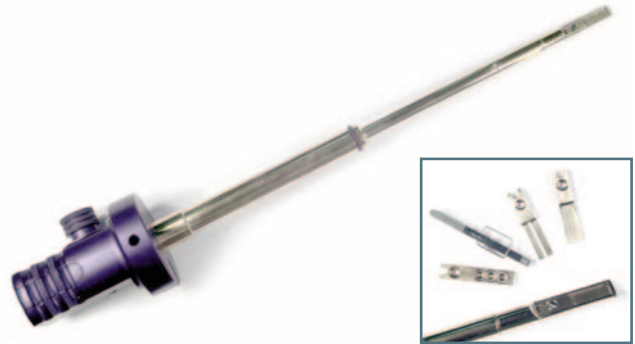
A three position insert which will fit standard JEOL 2 position holders as a direct replacement.

Specimens are held in place with our push fit, easy to use circlips. The circlip extraction tool, Cat. #EMS016 is needed to install and remove circlips.



Cat. No.	Description	Qty.
EMS056	JEOL 3-Position Grid Insert	each

Philips Bulk Sample Holder for Compustage



A single-tilt multi-functional sample holder for use in SEM or TEM modes. Includes slit serial section tip, 10 bulk, and a TEM 3.05 mm grid holder for use with TEM or STEM. Comes supplied in its own mahogany box, with a loading stand, and a circlip extraction tool.

Cat. No.	Description	Qty.
EMS054	Philips Bulk Sample Holder for Compustage	each

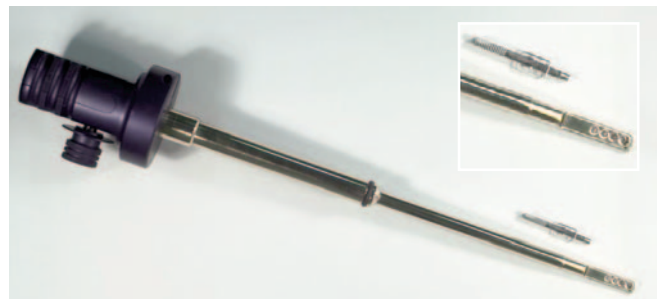
Philips Single Tilt Single-Sample Holder



A single tilt single sample holder. Will accommodate 3 mm grids. Grids are held in place by easy to remove circlips. Comes complete with loading stand, circlip extraction tool, and is supplied in its own box. Suitable for 400 and non-compustage microscopes.

Cat. No.	Description	Qty.
EMS021	4-Position Multi-Sample Holder	each

Philips 4-Position Multi-Sample Holder

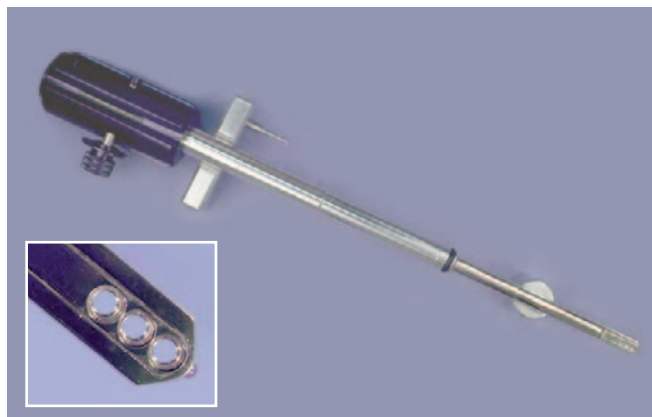


A single tilt multi-grid holder. Will accommodate 4 grids with easy reproducible movement between each specimen. It is ideal for scanning through serial samples or for comparing against standards.

Grids are held in place by easy to remove circlips. Comes complete with loading stand, circlip extraction tool, and is supplied in a mahogany box. Suitable for 400 and non-compustage microscopes.

Cat. No.	Description	Qty.
EMS020	Philips 4-Position Multi-Sample Holder	each

Hitachi 3-Position Multi-Sample Holder



A single tilt multi-grid holder. Will accommodate 3 grids with easy reproducible movement between each specimen. It is ideal for scanning through serial samples or for comparing against standards.

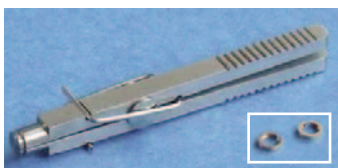
Grids are held in place by easy to remove circlips.

Comes complete with loading stand, circlip extraction tool, and is supplied in a mahogany box.

Cat. No.	Description	Qty.
EMS022	Hitachi 3-Position Multi-Sample Holder	each

3 mm Circlips and Insertion Tool

Circlips are for all EMS TEM sample holders and specimen rods. They are made from heat treated Beryllium copper.



The Circlip extraction tool is for removing our Circlips from all TEM sample holders.

Cat. No.	Description	Qty.
EMS015	3 mm Circlips	each
EMS016	Circlips Insertion Tool	each

TEM Grid Holder on a Pin

This EMS new release allows for the holding of up to 4 grids. Made from Aluminum with a brass Screw this holder allows you to image and analyze specimens on TEM Grids in the SEM. The Overall diameter of the holder is 1" (25mm) with a 1/8" Pin (3.2mm) and a longer pin 0.6" (15mm). The Grid locations are all numbered



Cat. No.	Description	Qty.
75949-03	TEM Grid Holder on Pin	each

TEM Grid Freeze Drying Holder

Freeze drying holder to hold 24 standard TEM grids.



Cat. No.	Description	Qty.
EMS063	TEM Grid Freeze Drying Holder	each

YOU MAY NEED...



Poseidon Select Toolkit

All the tools you need to perform in situ liquid electron microscopy with the Poseidon Select TEM Holder. These tools, specifically recommended by the manufacturer to work best with the Poseidon Select system, are available individually or in a convenient kit.



Cat. No.	Description	Qty.
75958	Poseidon Select Toolkit	kit
Contains all the items listed below...		
75958-01	Small Volume Pipette 0.1-2µl — Autoclavable. Small volume allows for precise deposition of sample onto the Poseidon E-chip. Requires compatible pipette tips	each
75958-02	Pipette Tips — 10 ul disposable pipette tips, required for the small volume pipette.	250/pk
75958-03	PEEK Tubing Cutter — used to safely cut PEEK tubing without crimping	each
75958-04	PTFE Dish — 60 mm diameter 25 ml capacity. Used to clean photoresist off E-chips. Two are required, one for acetone to dissolve the resist and one for methanol to ensure there is no acetone residue.	each
75958-05	Watch Glass — 75 mm diameter. Used to plasma clean E-chips to ensure they are clean and hydrophilic. Curved watch glass makes placing and picking up E-chips easier.	12/pk
75958-06	Torque Screw Driver — for tightening lid screws.	each
75958-07	Torque Driver Bit — for Torque Screw Driver	each
75958-08	Torque Driver Adapter — Insert Bit 1/4" Dr Hex Adapters. Adapter holds the torque driver bit, so it can be inserted into the torque driver	each
78325-29	Style 2A Straight-Tip PVDF Tweezers — Carbon tip tweezers help to avoid chipping the E-chip silicon	each
78325-41	Style 7 Curved-Tip PVDF Tweezers — Carbon tip tweezers help to avoid chipping the E-chip silicon	each

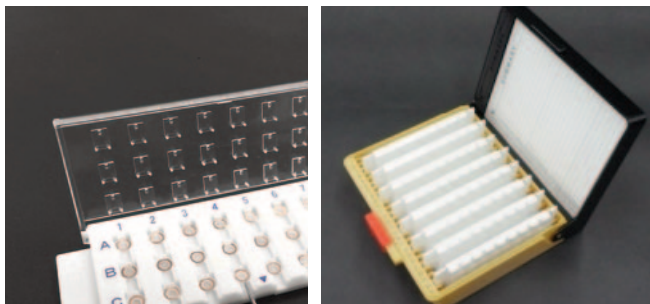
GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Storage & Transport

Horizontal Grid Box

Slide-in type

These grid boxes offer easy handling of the grids without damaging the support film.



Cat. No.	Description	Qty.
71161-01	Horizontal Grid Box	each
71161-02	Horizontal Grid Boxes	3/pk
71161-03	Horizontal Grid Boxes in Case	8/pk

EMS25 TEM Grid Storage Box

The EMS25 is a small capacity grid storage box, designed as a low alternative to larger grid boxes where extra storage capacity is not required.



The box has a sliding cover, allowing access to 5 slots at a time.

Each diamond shaped hole is capable of storing a 3.05 mm or 2.3 mm diameter grid. Storage referencing is managed via recessed alpha numeric indexing on the sides of the box.

The box contains two side features, allowing for easier handling during specimen removal, as well as a matte strip for extra notation.

The EMS25 is also available with a unique number printed in blue on the face, code EMS25BN; batches with sequential numbers are available. Both boxes come with a durable 25 column card for record keeping.

Our grid boxes are intended for use in both routine grid handling and for long term grid storage. Their compact flat shape and low cost make them well suited for the transportation of coated grid products and for the long term storage of catalogued specimens.

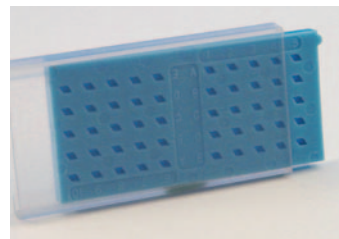
Specifications:

Size	56 mm (L) x 36 mm (W) x 6 mm (D)
Weight	9 grams
Materials	Base: ABS-PHAT (Acrylonitrile Butadiene Styrene + Anti-Static Additive) Cover: Clear Polycarbonate

Cat. No.	Description	Qty.
71159	EMS25 TEM Grid Storage Box, 25 Capacity	each
71159-10	EMS25 TEM Grid Storage Box, 25 Capacity	1 dozen
71159-20	EMS25 TEM Grid Storage Box, 25 Capacity, w/number	each
71159-30	EMS25 TEM Grid Storage Box, 25 Capacity, w/number	1 dozen

Grid Storage Box, 50 Capacity

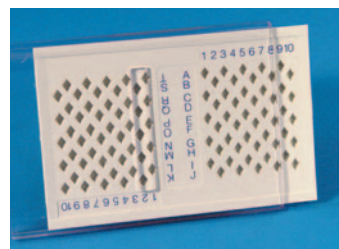
Storage for 50 grids in deep diamond-shaped wells. All wells are identified. The base is resistant to organics and reactions can be carried out on grid-mounted samples in the wells. Complete with grid recording card. Measures: 3"(L) x 1¹/₁₆"(W) x ⁵/₁₆"(H) (77x40x8mm)



Cat. No.	Description	Qty.
71150	Grid Storage Box, 50 Capacity	each
71152	Grid Storage Box, 50 Capacity	1 dozen

Grid Storage Box, 100 Capacity

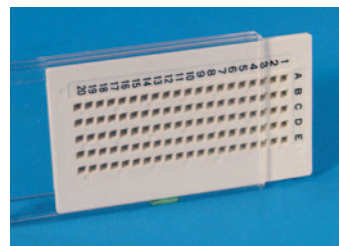
100 grids can be stored in identified diamond-shaped wells for daily handling or long-term storage. Complete with grid recording card. Measures: 3³/₁₆"(L) x 2¹/₁₆"(W) x ⁵/₁₆"(H) (85x58x7mm)



Cat. No.	Description	Qty.
71140	Grid Storage Box, 100 Capacity	each
71142	Grid Storage Box, 100 Capacity	1 dozen

Grid Storage Box, 100 Capacity

A newly designed grid storage box similar to the original LKB box. Made from a special plastic that minimizes static. Complete with grid recording card. Measures: 8cm(L) x 5cm(W) x 7mm(T)

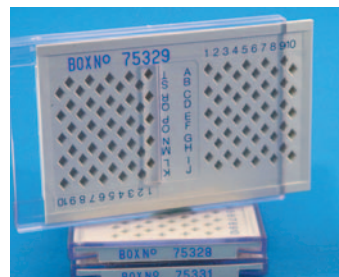


Cat. No.	Description	Qty.
71155	Grid Storage Box, 100 Capacity	each
71156	Grid Storage Box, 100 Capacity	1 dozen

Numbered Grid Storage Box, 100 Capacity

The standard 100 capacity grid storage box with a unique number printed on the face and on one end.

- Eliminates the placement of the specimen grid in the wrong box.
- Easy retrieval of grid box from storage.
- Complete with grid recording card.



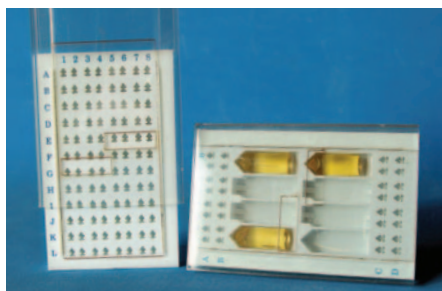
Cat. No.	Description	Qty.
71137	Numbered Grid Storage Box, 100 Capacity	each
71138	Numbered Grid Storage Box, 100 Capacity	10/lot
71139	Numbered Grid Storage Box, 100 Capacity	100/lot

GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Storage & Transport (continued)

III Multipurpose Electron Microscope Specimen Box – MEM Grid Box

A newly designed Grid Box with safety, ease and convenience in mind – this multipurpose electron microscope specimen grid box is one of the most desirable boxes on the market.



- Eliminates the chances of tweezers insertion damaging the grids – The ‘tweezers slot’ and ‘grid slot’ are in a separate location. The tweezers are only able to grip the edge of the grid enabling it to be picked up
- Grids stored no longer jump out of the box while you remove the cover – Between the body of the box and the sliding lid, there is a separate plastic cover, which allows for only four slots being exposed at a time
- The Grid Record Card is stored safely by insertion along the reverse side of the box
- MEM-96 – will able to store up to 96 grids
- MEM-32 – will able to store up to 32 grids with 8 Blocks
- Measures: 81mm L x 54mm W x 6mm thick

Cat. No.	Description	Qty.
71164-01	MEM-96 Grid Storage Box	each
71164-10	MEM-96 Grid Storage Box	10/pk.
71165-01	MEM-32 Grid Storage Box	each
71165-10	MEM-32 Grid Storage Box	10/pk.

III TEM-Specimen Grid Box – SB50

This newly designed TEM grid storage box is for routine handling and long term storage of 50 standard size TEM grids. The ergonomic design overcomes the disadvantages of the more conventional ‘sliding cover’ design. This new box has a unique number on the face and on one end.



- The blue arrow at the 12:00 o'clock position indicates the park position for the cover when not in use. This is a firm grip ‘click’ position and it cannot be moved accidentally, thus preventing spillage.
- The 50 diamond-shaped slots have an alphanumeric referencing system. Each box is supplied with an index record card for additional information.
- The clear cover can be rotated smoothly through 360° once the slight initial resistance of the park position has been overcome, exposing a maximum of 2 or 3 slots at any one time.
- The base material has anti-static properties. The clear cover has self-lubricating properties, which reduces friction, enabling the cover to move freely while remaining in close contact with the face of the base.
- Stackable — the base fits precisely over the face of another box.

Specifications

Size (mm)	75 (L) x 65 (W) x 6.5 (D)
Weight	22 grams
Materials	Base: ABS-PHAT (Acrylonitrile Butadiene Styrene + Anti-Static Additive) Cover: CAB (Cellulose Acetal Butyrate)

Ordering Information

Cat. No.	Description	Qty.
71135-01	SB50 Grid Storage Box	each
71135-12	SB50 Grid Storage Box	12/bx
71136-01	SB50N Grid Storage Box with Unique Number	each
71136-12	SB50N Grid Storage Box with Unique Number	12/bx

III EMS Multifunctional Vacuum Desiccator



73879-01

Our versatile vacuum desiccator has been designed to be used in both SEM and TEM Applications. With the change of an accessory the desiccator is capable of being used with grids, pin mounts as well as Hitachi M4 Mounts.

The ability to store your grids and or mounts under vacuum eliminates any dust particles and contamination which may be airborne. The base desiccator may pump down to 10⁻³ mbar and can hold vacuum for up to one year.

The unit is made from Red Anodized aluminum and it measures 76 mm x 35 mm (3" x 1.4") and has a standard vacuum connection (¼") (6.35 mm) barb fitting.

The desiccators may be used with any laboratory pump or our 94588 series of pumps.

Features

- Versatile holder for the storage as well as shipping of samples
- Prevents oxidation
- Prevents dust and contamination of the grids and mounts
- Comes complete with an acrylic lid to enable visualization of samples



73879-02

Ordering Information

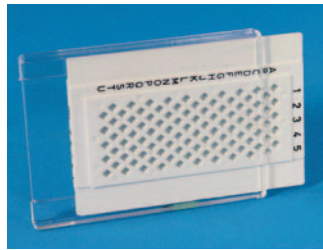
Cat. No.	Description	Qty.
73879-01	EMS Multifunctional Vacuum Desiccator, TEM Grids	each
73879-02	EMS Multifunctional Vacuum Desiccator, Pin Mounts	each
73879-03	EMS Multifunctional Vacuum Desiccator, Hitachi M4	each

GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Storage & Transport (continued)

THE ORIGINAL LKB Grid Storage Box

For years, The LKB Grid Storage Box is the one that everyone is looking for. Now it is available again from EMS. The box is made from ABS (a copolymer of Acrylonitrile, Butadien and Styrene) which will not tolerate temperatures above 70°C, while the lid is made of Polymethacrylate (Flexiglas, Perspex), which should not be exposed to temperatures above 45°C. Neither the box or the lid will resist organic solvents. The box consists of 100 diamond shaped holes for storing up to 100 EM grids, either 3.05mm or 2.3mm in diameter. The box measures 3" (75mm)(L) x 2½"(55mm)(W) x ¼"(7mm)(H) and it comes complete with 10 index cards.



Cat No.	Description	Qty.
71147-01	LKB 100-Grid Storage Box	each
71147-12	LKB 100-Grid Storage Box	100/pk

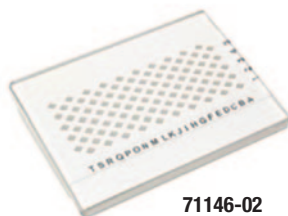
EMS 50 and EMS 100 Capacity Inexpensive Grid Storage Boxes

The EMS50 and EMS100 TEM Grid Storage Boxes are used for the storage of TEM grids for routine grid handling, transport and long term TEM grid storage for standard grids that are 3.05mm in diameter.

The box has a simple number/letter combination printed on the side of the body. Dimensions for both boxes are: 3"(75mm) x 2½"(55mm) x ¼"(6.5mm) and they are anti static treated.



71146-01



71146-02

Cat No.	Description	Qty.
71146-01	EMS 50 Grid Box	each
71146-02	EMS 100 Grid Box	each

Grid Transporting Box

This unique Box allows for the storage and transportation of grids without any worry of them moving around or being damaged. The Plate is made from Silicone and has 54 individual compartments 10mm in size. Each compartment can hold 3 grids and the grids can be easily picked up from the Silicone surface.



Cat No.	Description	Qty.
71173-01	Grid Transporting Box	each

Dial-A-Grid Storage Modules

A two tone color coded plastic box with insert which has 24 letter-labeled crossed slots, where the grids can be stored. A rotating protection plate covers the slots and allows for exposure of one grid at a time.

Measures: 2½" (L) x 1¾" (W) x ½" (H) (57 x 45 x 12.5mm)



71148-01

Cat No.	Description	Qty.
71148-01	BEEM® Dial-A-Grid Storage Box	each
71148-05	BEEM® Dial-A-Grid Storage Box	50/pk
71148-10	BEEM® Dial-A-Grid Storage Box	100/pk

Beem® Is A Registered Trademark of Better Equipment For Electron Microscopy, Inc.

BEEM® Dial-A-Grid and Block Storage Modules

The same as Dial-A-Grid Module but with two additional cavities for block storage.



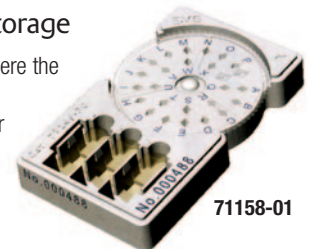
71149-01

Cat No.	Description	Qty.
71149-01	BEEM® Dial-A-Grid & Block Storage	each
71149-05	BEEM® Dial-A-Grid & Block Storage	50/pk
71149-10	BEEM® Dial-A-Grid & Block Storage	100/pk

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EMS Dial-Grid-N-Block-Storage

24 slots labeled with letters from A-X where the grids can be stored and rotated for easy access as well as 3 additional cavities for block storage. Available with and without a unique identification number.



71158-01

Cat No.	Description	Qty.
71158-01	EMS Dial-Grid-N-Block Storage	each
71158-05	EMS Dial-Grid-N-Block Storage	50/pk
71158-10	EMS Dial-Grid-N-Block Storage	100/pk
71158-15	EMS Dial-Grid-N-Block Storage/With Number	each
71158-20	EMS Dial-Grid-N-Block Storage/With Number	50/pk
71158-25	EMS Dial-Grid-N-Block Storage/With Number	100/pk

FIB Grid Box for Lift-Out Grids or Half Grids

This four-position grid box with lid holds FIB lift-out grids or half grids. With a cavity depth of only 1.7mm, grids won't rotate inside the box. Loading or unloading FIB grids can be done with relative ease using sharp tweezers.



Cat No.	Description	Qty.
71166-61	Four-Position FIB Grid Box	each

GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Storage & Transport (continued)

III Cryogenic Grid Storage Boxes, Metal

These cryogenic grid boxes are used for storage and transfer of standard grids as well as AutoGrid rings. These boxes are durable and long-lasting. Each has a unique number, to allow for tracking.

- 4-well design
- Made from medical-grade aluminum (cryogenic-grade)
- Autoclavable
- Solvent resistant
- Pin-type lid



Cat No.	Description	Qty.
71165-05	Cryogenic Grid Storage Boxes, Metal	each

III Cryogenic Grid Storage Boxes

Specimen grid boxes for storing or transferring cryogenic TEM specimen grids.

- Four diamond shaped slots
- Non-static clear covershield held in place with stainless steel screw, tapped in the center of the box
- Box fits the FEI Vitrobot™, Gatan 626™, Gatan 3500™
- Available with lid, pin-type lid, or without lid



Cat No.	Description	Qty.
71166-10	Cryo Grid Box, Round, w/Lid	each
71166-10-G	Cryo Grid Box, Round, w/Lid, Green	each
71166-10-W	Cryo Grid Box, Round, w/Lid, White	each
71166-10-W-GB4R	Cryo Grid Box, Round, w/Lid, White	each
71166-20	Cryo Grid Box, Square, w/Lid	each
71166-30	Cryo Grid Box, Round, wo/Lid	each
71166-40	Cryo Grid Box, w/Pin Type Lid for FEI Vitrobot	each
71166-50	Pin Type Lid only for Cryo Grid Box	each
71166-50B	Cryo Grid Box, w/Pin Type Lid	each
71166-60	Cryo Grid Box, w/Lid, Sq for Gatan CT3500	each

III Gripper Tool for Cryo Grid Boxes



Use this tool to open the lid of cryogrid boxes. It features a spring loaded vise that grips the lid securely and a ribbed barrel for ease in unscrewing the lid. Made of high quality aluminum, it can be used with liquid nitrogen. Can also be used to carry the cryo grid box.

Cat No.	Description	Qty.
71166-SP	Gripper Tool for Cryo Grid Boxes	each

III Economy Gripper for Cryo Grid Boxes



Use this tool to open the lid of cryogrid boxes. It features a spring loaded vise that grips the lid securely and a ribbed barrel for ease in unscrewing the lid. Made of plastic. Can also be used to carry the cryo grid box.

Cat No.	Description	Qty.
71166-GP	Economy Gripper Tool for Cryo Grid Boxes	each

III Cryo Grid Box Handling Tool



This tool has one end which is threaded and fits into the center hole of the Cryogenic Grid Storage Box (where the screw goes in to secure the lid) for moving the box in and out of the cryogenic chamber.

Cat No.	Description	Qty.
71165-50	Cryo Grid Box Handling Tool	each

III AutoGrid Compatible Cryo Grid Box

NEW

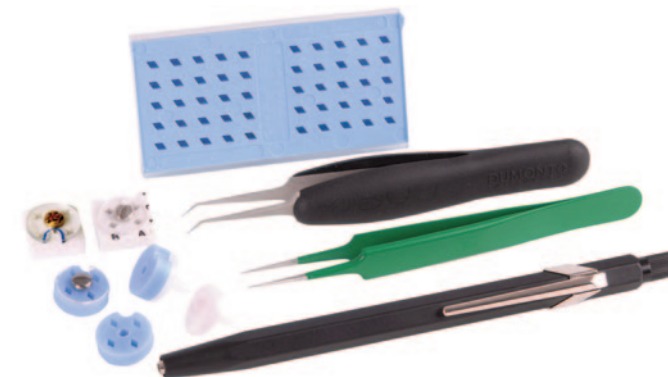


Features 4 large diamond-shaped cavities that accommodate larger diameter AutoGrids.

Cat No.	Description	Qty.
71166-AG	AutoGrid Compatible Cryo Grid Box	each

III EMS Cryo Preparation Kit

Electron Microscopy Sciences is proud to introduce a cryo starter kit which includes all of the supplies necessary to begin Cryo EM. The kit includes a variety of our Cryogenic Grid Storage Boxes, Manipulation Tweezers and Gripper Tools, as well as our C-Flat Holey Carbon Cryo Grids. The Tweezers we are using are coated as well as anti-magnetic.



The kit comes with the following pieces in a small display box:

- Cryo Grid Box, Round, w/Lid
- Cryo Grid Box, Square, w/Lid
- Cryo Grid Box, Round, wo/Lid
- Cryo Grid Box, w/Pin Type Lid for FEI Vitrobot
- Cryo Grid Box, w/Pin Type Lid
- Cryo Grid Box, w/Lid, Square for Gatan CT3500
- Gripper Tool for Cryo Grid Boxes
- C-flat™ Holey Carbon Grids for TEM - Copper Only (CF-222C-25)
- ESD Ergonomic Tweezers (0304-5SAESD-ET2)
- ESD Epoxy-Coated Tweezers (0302-5-CO)

Cat. No.	Description	Qty.
71166-K	Cryo Preparation Kit	kit

Additional Kit Supplies

71166-10	Cryo Grid Box, Round, w/Lid	each
71166-10-G	Cryo Grid Box, Round, w/Lid, Green	each
71166-10-W	Cryo Grid Box, Round, w/Lid, White	each
71166-20	Cryo Grid Box, Square, w/Lid	each
71166-30	Cryo Grid Box, Round, wo/Lid	each
71166-40	Cryo Grid Box, w/Pin Type Lid for FEI Vitrobot	each
71166-50	Pin Type Lid only for Cryo Grid Box	each
71166-50B	Cryo Grid Box, w/Pin Type Lid	each
71166-60	Cryo Grid Box, w/Lid, Sq for Gatan CT3500	each
71166-SP	Gripper Tool for Cryo Grid Boxes	each

C-flat™ Holey Carbon Grids for TEM - Copper Only

Cat. No.	Hole Size	Hole Spacing	TEM mesh	TEM Grid	Qty.
CF-222C-25	2.0 µm	2.0 µm	200	Cu	25/pkg

ESD Tweezers

Cat. No.	A mm	B mm	Handle	Alloy	Qty.
0304-5SAESD-ET2	0.06	0.10	Black	Antimagnetic	each
0302-5-CO	0.06	0.1	Epoxy Coated	Inox 02	each

GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Storage & Transport (continued)

EMS Cryo Pucks G2

Organized storage and transport for Cryo-EM specimen grids under cryogenic conditions.

We now offer a broad selection of kits and bundles to meet your needs.

- 12 wells per puck for Cryo Grid Boxes
- Each puck has a unique alpha-numeric code for easy identification
- Indexed wells for sample tracking
- Holds round Cryo Grid Boxes
- Puck depth accommodates pin type lid style Cryo Grid Boxes
- When using Cryo Grid Boxes with flat-style lids, you can store up to 24 Cryo Grid Boxes per puck
- Special tweezer slots allow easy and secure removal of Cryo Grid Boxes
- Shelved shipping Cane holds up to 8 pucks
- Shelved Storage Cane hold 10 packs
- Magnets for strong puck retention but easy removal
- 2D Barcoding and custom puck serialization for advanced sample tracking
- See-through, affixed lid retains liquid nitrogen during transfers to protect samples
- Lid-lock feature provides easy and secure loading
- 10 Unique puck colors available for easy identification (available upon request)

Limiting exposure to ambient conditions is recommended, but brief periods during puck placement and retrieval has not resulted in frost or ice accumulation.



Ordering Information

Contact us for ordering pucks in a specific color combination. Available colors include: Red, Blue, Purple, Grey, Black, Gold, Green, Violet, Brown, Orange.

EMS Cryo Pucks G2 Basic Starter Set

Includes:

- (10) G2 EMS Cryo Pucks
- (1) Shelved Storage Cane
- (1) Shelved Puck Shipping Cane
- (1) Angled Cryo-Tongs

Cat. No.	Description	Qty.
71168-00	1-color	set
71168-03	rainbow	set

EMS Cryo Pucks G2 Advanced Starter Set

Includes:

- (10) G2 EMS Cryo Pucks
- (1) Puck Dewar and Insert
- (1) Shelved Puck Shipping Cane
- (1) Cryo-EM Grid Box Tweezers
- (1) Shelved Storage Cane
- (1) Screwdriver for Lid Lock
- (1) Angled Cryo-Tongs
- (1) Puck & Cane Tracking Log Book
- (1) Grasping Tongs

Cat. No.	Description	Qty.
71168-04	1-color	set
71168-05	rainbow	set

EMS Cryo Pucks G2 Facility HC34/VHC35 Starter Set

Includes:

- (60) G2 EMS Cryo Pucks
- (1) Puck Dewar and Insert
- (1) Shelved Puck Shipping Cane
- (1) Cryo-EM Grid Box Tweezers
- (6) Shelved Storage Cane
- (1) Screwdriver for Lid Lock
- (1) Angled Cryo-Tongs
- (1) Puck & Cane Tracking Log Book
- (1) Grasping Tongs
- (1) Barcode Reader

Cat. No.	Description	Qty.
71168-06	1-color	set
71168-14	rainbow	set

EMS Cryo Pucks G2 Facility HC34/VHC35 Advanced Set

Includes:

- (60) G2 EMS Cryo Pucks
- (2) Cryo-EM Grid Box Tweezers
- (1) Shelved Puck Shipping Cane
- (2) Screwdriver for Lid Lock
- (6) Shelved Storage Canes
- (2) Puck & Cane Tracking Log Book
- (2) Angled Cryo-Tongs
- (1) Barcode Reader
- (2) Grasping Tongs
- (1) HC34 Dewar & Roller Base
- (2) Puck Dewar and Insert
- (1) CX100 Dryshipper and Case

Cat. No.	Description	Qty.
71168-15	1-color	set
71168-16	rainbow	set



GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Storage & Transport (continued)

III EMS Cryo Pucks G2 (continued)

EMS Cryo Pucks G2 Facility HC35 Starter Set

Includes:

- (100) G2 EMS Cryo Pucks
- (1) Shelved Puck Shipping Cane
- (10) Shelved Storage Cane
- (1) Angled Cryo-Tongs
- (1) Grasping Tongs
- (1) Puck Dewar and Insert
- (1) Cryo-EM Grid Box Tweezers
- (1) Screwdriver for Lid Lock
- (1) Puck & Cane Tracking Log Book
- (1) Barcode Reader

Cat. No.	Description	Qty.
71168-17	1-color	set
71168-18	rainbow	set

EMS Cryo Pucks G2 Facility HC35 Advanced Set

Includes:

- (100) G2 EMS Cryo Pucks
- (1) Shelved Puck Shipping Cane
- (10) Shelved Storage Canes
- (2) Angled Cryo-Tongs
- (2) Grasping Tongs
- (2) Puck Dewar and Insert
- (2) Cryo-EM Grid Box Tweezers
- (2) Screwdriver for Lid Lock
- (2) Puck & Cane Tracking Log Book
- (1) Barcode Reader
- (1) HC35 Dewar & Roller Base
- (1) CX100 Dryshipper and Case

Cat. No.	Description	Qty.
71168-19	1-color	set
71168-20	rainbow	set



71168-13



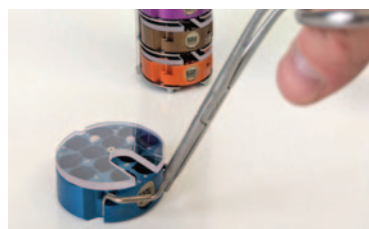
71168-42



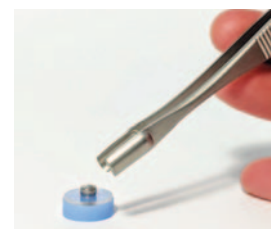
71168-11



71168-10



71168-25



71168-39

Cryo Pucks and Canes

Cat. No.	Description	Qty.
71168-21	EMS Cryo Pucks G2	each
71168-22	EMS Cryo Pucks G2	10/pk
71168-25	EM Puck Grasping Tongs G2	each
71168-09	G2 Shelved Storage Cane - HC34/VHC35	each
71168-27	G2 Shelved Storage Cane - HC35	each
71168-28	G2 Shelved Storage Cane - Custom	each
71168-12	G2 Shelved Puck Shipping Cane - CX100	each
71168-11	Bent Cryo Tong	each

Cryo Equipment

71168-13	Cryo Express Dry Shipper with Case	each
71168-32	HC34 34 liter High-Capacity Refrigerator	each
71168-33	HC35 35 liter High-Capacity Refrigerator	each
71168-34	VHC35 Very High Capacity Refrigerator w/ Canisters (Holds up to 6 Puck Storage Canes)	each
71168-35	Roller Base for HC34, HC35 & VHC35	each

Cryo Puck Accessories

71168-08	EMS Cryo Puck Storage Case	each
71168-10	Double Puck Loading Dewar with Lid	each
71168-38	Dewar Insert	each
71168-39	Tweezers	each
71168-40	Lid Lock Screwdriver	each
71168-41	Puck and Cane Log Sheets	each
71168-42	Barcode Reader	each

Remaining EMS Cryo Pucks G1

While supplies last...

71168-02	EMS Cryo Pucks G1	each
71168-07	EMS Cryo Pucks G1	7/pk

GRID PREPARATION SUPPLIES AND ACCESSORIES

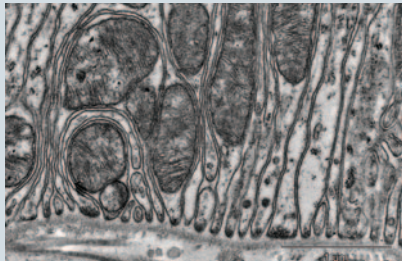
Grid Staining & Mounting

Overview

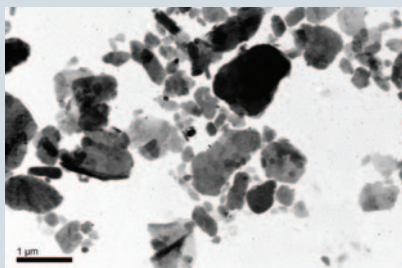
The mPrep™ System saves you effort while protecting and keeping track of valuable samples. The system features two types of purpose-built, microliter-volume capsules – one for specimens, the other for grids. Capsules attach to standard pipettors, which are used to conveniently deliver reagents in measured amounts.

Users get consistent sample preparation with almost no direct handling of specimens and grids. Once the tissue or grid is in its own, labeled capsule, you don't have to touch it again during processing. It is safe, easy-to-handle and clearly labeled. The small, enclosed capsule, reduces reagent consumption. The system adapts to any protocol for biospecimen preparation, grid staining or immuno-labeling. Multi-channel pipettors enable users to increase throughput, with virtually no extra effort.

Applications: TEM



Kidney (TEM)



Nanoparticles (TEM negative stain)

- As few as two human touches from microtome to microscope – reduces damage and loss
- Grids and capsules labeled for easy tracking from start to storage
- Capsules attach to common lab pipettors for controlled reagent timing and minimal reagent consumption
- Parallel processing



mPrep™ System for Specimen Preparation and Grid Staining

Consistent sample preparation with almost no direct handling of specimens and grids

mPrep/s™ Specimen Processing Capsules

mPrep/s™ capsules allow users to fix, dehydrate and embed specimens in a single vessel. They can be used in two ways. The first method is to entrap specimens in the bottom of the capsule using the removable, adjustable screen with the hand-held Insertion Tool (85010-03). The second method is to flex the screen open using the mPrep/s™ Workstation* (85010-06). With the screen opened, the user places a specimen in the screen and orients it to the desired position within the capsule. Once the



Capsule



Screen

screen closes on the specimen, it is held in place throughout fixation, embedding, and sectioning. No additional embedding molds are required, and the capsule itself easily fits in the microtome chuck. This capsule is highly recommended for transmission and scanning electron microscopy, but can also be used for any sample preparation.

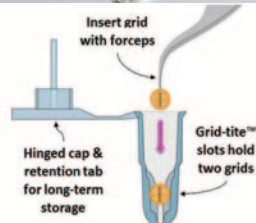
mPrep/s™ capsules are available in 24/packs or bulk. The hand-held Insertion Tool (85010-03), the Workstation* (85010-06), and additional recommended accessories for use with the mPrep/s™ capsule are located below.

* The Workstation is required to make use of the orientation feature of the mPrep/s™ screen.



Insertion Tool

Cat. No.	Description	Qty.
85010-01	mPrep/s™ Capsules with screens	24/pk
85010-02	mPrep/s™ Capsules with screens	96/pk
85010-03	mPrep/s™ Insertion Tool	each



mPrep/g™ Grid Processing Capsules

Each capsule can hold one or two TEM grids securely for staining, immuno-labeling and labeled storage. Grids are protected from loss, misidentification, and damage. Grid-tite™ slots keep grids safe even if an open capsule is dropped.

Grids require handling only twice: when inserted into capsules and when placed in the TEM.

Using a multi-channel pipettor, processing up to 24 grids simultaneously takes no more effort than a single grid. Reagent consumption is as little as 20µl per grid. The chance of grid damage or loss is greatly reduced using these capsules. See mPrep/g™ Pipettor Kits (85010-07 and 85010-08) and additional accessories below.

Cat. No.	Description	Qty.
85010-04	mPrep/g™ Capsules	16/pk
85010-05	mPrep/g™ Capsules	96/pk

GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Staining & Mounting (continued)

III mPrep/s™ WorkStation for TEM and SEM

Everything you need to work efficiently while preparing your samples using mPrep/s™ capsules is easily accomplished with the mPrep/s™ WorkStation. Simply load the capsule onto the built-in insertion tool at the center of the workstation, detach the screen from the capsule, use the lever to open the screen and insert the specimen. Then release the lever and re-attach the capsule. Once loaded, the sample requires no additional handling – even for TEM embedding or SEM mounting.

The mPrep/s™ WorkStation's polyethylene surface minimizes dulling of dissection tools and is fully immersible for easy cleaning between uses. Molded into the surface are 12 dissection wells to organize your specimens and keep them wet if desired. At the back, 12 capsule wells and 3 screen holders conveniently hold these prior to use. On either side of the workstation, a total of 24 capsule wells can hold loaded capsules and keep them wet while loading into the channels of the pipettor. Single and multichannel pipettor kits are sold separately. Additional recommended accessories for use with the mPrep/s™ Workstation are shown below.

Features

- Specimens may be oriented using several methods
- Streamlines specimen processing from dissection to reagent processing
- Once loaded in capsules, specimens are not touched again – even for TEM embedding or SEM mounting
- Dissect and load specimens wetted by buffers or fixatives
- Directly load capsules onto pipettor from Workstation

Applications

- Capsule-based Processing of Biological Tissue for TEM
- Biological tissues – fix and critical point dry (CPD)
- Bio tissue cryo-facing
- Polymer cross-section preparations

Cat. No.	Description	Qty.
85010-06	mPrep/s™ Workstation	each

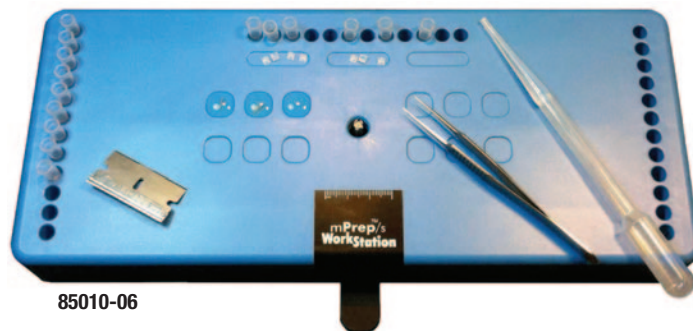
III mPrep™ Pipettors

Choose from either single- or multi-channel pipettors built around mPrep/s™ or mPrep/g™ capsules.

- Single channel 200 µl pipettor
- Eight-channel 200 µl pipettor



Cat. No.	Description	Qty.
85010-07	mPrep™ Pipettor, Single Channel	each
85010-08	mPrep™ Pipettor, Multichannel	each



III mPrep™ System Accessories

(mPrep/s™ and mPrep/g™ compatible)

mPrep Filter-Couplers

Filter couplers prevent the introduction of damaging reagents into pipettors. They also improve the fit of mPrep/g™ capsules on some pipettors. Pack includes 16 filter couplers and a capsule storage box.

Available in two pore sizes:

1. Standard mPrep/f30™: nominal 30 µm pore size filter appropriate for most applications.
2. Extreme mPrep/f13™: nominal 13 µm pore size filter for use with biohazards and very aggressive reagents.



85010-10, -11

mPrep™ Tousimis® Capsule Holder

Holds up to 6 mPrep/s™ or mPrep/g™ capsules in Tousimis® CPD apparatus



85010-13

Reagent Reservoirs

Chemically resistant 25ml reservoirs, 50 per pack, HDPE



85010-14

mPrep™/Bench

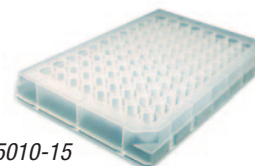
96-well silicone rack provides tight seal to capsule bottoms during incubations or transfer of fluid-filled capsules to ovens and incubators. Autoclavable.



85010-16

Microwell Plates

Chemically resistant 96-well plates, 10 per pack, polypropylene



85010-15

Cat. No.	Description	Qty.
85010-11	mPrep/f30™ Standard Filter-Couplers	16/pk
85010-12	mPrep/f13™ Extreme Filter-Couplers	16/pk
85010-13	Tousimis® Capsule Holder	each
85010-14	Reagent Reservoirs	50/pk
85010-15	Microwell Plates, PP, NS, 500uL	10/pk
85010-16	mPrep™ Bench	each
85010-17	Microwell Plates, square well, 1.2ml	10/pk
85010-18	12-channel reagent reservoir, polypropylene	each
85010-19	X-Pierce hairline cross-cut piercable film for automation	each
85010-20	Piercable aluminum plate sealing foil sheets, non-sterile	each

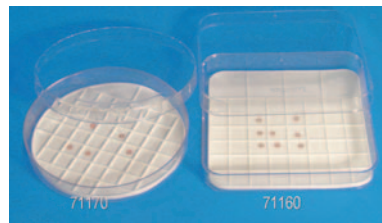
GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Staining & Mounting (continued)

III Grid Mats

White silicone rubber mats, with numbered compartments. Good for organizing grids. They will not slide or jump between compartments. Also ideal for staining grids. Easy to pick up grids without damaging forcep tips. Mats are available for square and round petri dishes, (100mm diameter, 115mm high).

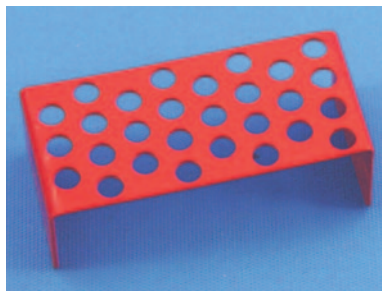
Cat. No.	Description	Qty.
71160	Square Grid Mat	each
71162	Square Grid Mat	1 dozen
71170	Round Grid Mat	each
71172	Round Grid Mat	1 dozen



III EMS Domino Rack

The EMS Domino rack is "U" shaped and made from an aircraft alloy sheetstock with serial perforations; thermally bonded spaceage copolymer; 5mm diameter holes, 28 holes per rack. The formvar film cast on the rack will stretch across a series of smooth edged holes forming a flat, wrinkle free film that is ready for grid mounting. The Domino Rack allows the sections within the slot to dry flat and wrinkle free; it reduces the film and section contamination to negligible levels. The size of the rack is 54mm (L) x 17.5mm(H) x 25.5mm (W) Moran, D.T., and Rowley, J.C., (1987). "Biological Specimen Preparation for Correlative Light and Electron Microscopy in Biology: Microscopy and Methods, ed. M.A. Hayat. Academic Press, New York./ pg 1-22

Cat. No.	Description	Qty.
70620	EMS Domino Rack	each
70621	EMS Domino Rack	10/lot



III Grid Staining Matrix System

This unique staining device allows you to stain up to 25 grids at one time or as little as one. The Matrix system has a simply alpha-numeric identification system. The unit is not solvent or chemically resistant to acids so all stains should be aqueous based only.

The system requires very little stain and you may use different vessels for each stain. The amount of volume of stain required is as follows:

21-25 grids: 11ml **16-20 grids:** 9ml **11-15 grids:** 7ml **06-10 grids:** 5ml **01-05 grids:** 3ml

Each system includes: Matrix Body, 2 each of the Staining Vessels, (Red and Blue)

Cat. No.	Description	Qty.
71179-01	Grid Staining Matrix System Kit	each
71179-05	Matrix Body with handle and cover	each
71179-06	Staining Vessels, 1 red and 1 blue	2/pk
71179-07	Staining Vessel, blue	each
71179-08	Staining Vessel, red	each



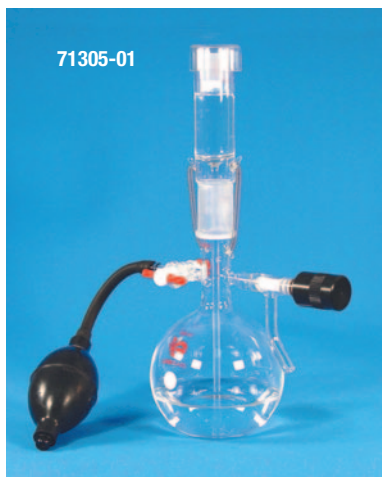
III Film Casting Device

An all glass apparatus. It casts uniformly thin films of parlodion, formvar, or butvar directly onto 1x3 microscope slides. The film casting solution can be used repeatedly. A built-in fine-pressure-release valve helps control the speed of drainage. The thickness of the film is controlled by the concentration of the film solution and the rate of the drainage. The unit requires 100mls of film casting solution to start.

The unit comes complete with: 500 ml capacity flask with built-in valves; Air-in and Air-out, Film casting Cylinder with Cover, and 75 cc Atomizer.

Cat. No.	Description	Qty.	Cat. No.	Description	Qty.
71305-01	Complete Film Casting Device	each	71305-06	Film Casting Cylinder Replacement	each
71305-04	500 ml Flask Replacement	each	60804	Atomizer Replacement	each

**EMS
EXCLUSIVE**



III All Glass Nebulizer

An all glass unit for the simple production of microdroplets. An object is held vertically in front of the nebulizer outlet and by squeezing the atomizer a fine spray is created. The nebulizer set comes with an All Glass Nebulizer bulb and Atomizer.

Cat. No.	Description	Qty.	Cat. No.	Description	Qty.
70505-01	Nebulizer Set	set	70506-01	Nebulizer Only	each
70505-05	Nebulizer Set	5 sets	70506-05	Nebulizer Only	5/pk
			60804	Atomizer	each



GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Staining & Mounting (continued)

EMS Grid Prep Holders

Electron Microscopy Sciences introduces unique preparation trays which may be used for staining and/or placing an evaporator for the coating of grids.

The trays have a M4 tapped hole in the center which allows for insertion of pin mount. They also have a screw pin in the middle that may be used as a handle for manipulating the trays.

They are made from medical grade aluminum and come in a plastic storage box.

Available in two sizes:

36 capacity: measures 1.688" (L) x 1.688" (W) x 0.250" Thick (43 mm x 43 mm x 6 mm)

81 capacity: measures 2.563" (L) x 2.563" (W) x 0.250" Thick (65 mm x 65 mm x 6 mm)



Cat. No.	Description	Qty.
71175-01	EMS Grid Prep Holder, 36 Capacity	each
71175-02	EMS Grid Prep Holder, 81 Capacity	each

Grids Staining Pad

Observing the ultrastructure of cells under an electron microscope is an important aspect of biological research, especially in the neurosciences.

Unfortunately, preparing a sample for a transmission electron microscope is a long and difficult process. This product was designed to simplify the preparation of samples and make the process more time efficient.



Cat. No.	Description	Qty.
71187	Grids Staining Pad	kit

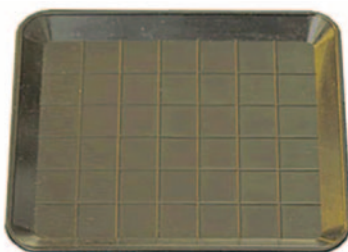
Picking Trays

These unique trays, which are available in either black rigid ABS plastic or aluminum in black or tan.

The trays feature 42 cells with a lip differentiating each cell. The cells measure 11 mm x 11 mm (7/16 x 7/16").

Tray measures 96 x 34 mm (3.78 x 1.34").

Trays perfect for placement of grids and storage of small components.



Cat. No.	Description	Qty.
71171-01	Picking Tray, Black ABS Plastic	each
71171-02	Picking Tray, Black Metal	each
71171-03	Picking Tray, Tan Metal	each

Modified Hiraoka Staining Kit

EMS is proud to introduce a modified Hiraoka Staining Kit that can stain up to 20 grids at a time. This kit encompasses all of the amazing qualities of the original Hiraoka Staining Kit with the enhanced features of the ability to autoclave and microwave the staining tray as well as the staining tray insert. The modified plate holder as well as the parafilm well holder are made from Delrin, while the staining tray and staining tray insert are made from polypropylene. (Chemically resistant, autoclavable, and microwave safe.)



Kit includes: Modified Hiraoka Staining Tray (6), Modified Plate Holder, Parafilm Well Holder, Staining Tray Space Insert (2), Grid Support Plate (2), Parafilm.

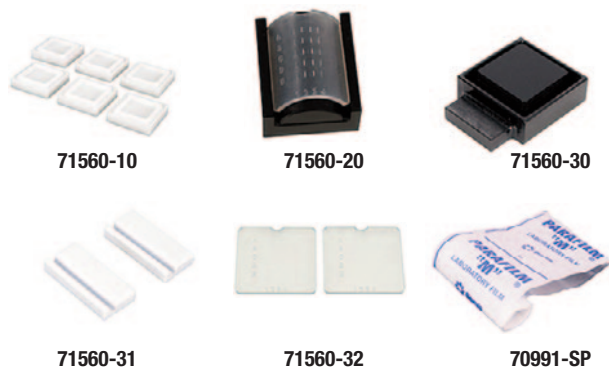
Dimensions of kit contents are as follows:

Modified Staining Tray: 46 x 46 x 11.5mm (1¾ x 1¾ x ½") thick

Modified Plate Holder: 45 x 38 x 32mm (1¾ x 1½ x ½") thick

Parafilm Well Mold: 53 x 40 x 17.5mm (2¼ x 1½ x ¾") thick

Staining Tray Space Insert: 29 x 14 x 4.5mm (1½ x ⅝ x ½") thick



Citations

Hiraoka JI. A holder for mass treatment of grids, adapted especially to electron staining and autoradiography. *Stain Technology* 1972; 47:297-301.

Seifert, P. Modified Hiraoka TEM grid staining apparatus and technique using 3D printed materials and gadolinium triacetate tetrahydrate, a nonradioactive uranyl acetate substitute. *Journal of Histotechnology*. 2017. 40 (4):130-135.

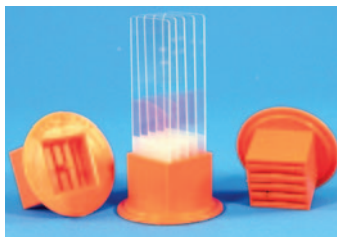
Cat. No.	Description	Qty.
71560-00	Modified Hiraoka Staining Kit	kit
71560-10	Modified Staining Tray	each
71560-20	Modified Plate Holder	each
71560-30	Parafilm Well Mold	each
71560-31	Staining Tray Space Insert	each
71560-32	Grid Support Plate	each
70991-SP	Parafilm M	5/pk

GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Staining & Mounting (continued)

Five-Slide Gripper

- The Five-Slide Gripper accommodates five microscope slides in one staining procedure.
- Fits most coplin and round-open staining jars.
- No need to remove slides for drying.
- Made from a special material which is resistant to all chemicals and solvents which are used in staining.
- Withstands drying temperatures up to 80°C



Cat. No.	Description	Qty.
71410-06	Five-Slide Gripper	6/pk

Plexiglas Microscope Slides

These plexiglass slides are 3 x 1" (75-25mm) and 1 mm thick. They prevent wrinkling and section loss while mounting sections on grids. The procedure is simple. **See our Technical Tip on page 15.**



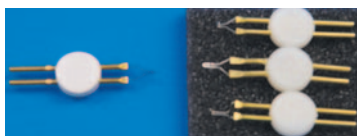
Cat. No.	Description	Qty.
71891-10	Plexiglass Microscope Slides	5/pk

Grid Coating Pen For TEM; Coat Quick "G"

The Coat-Quick "G" pen improves the adherence of tissue sections onto the grids. With a touch of the pen to the grid, a thin layer of coating is applied to the grid. Drying takes place in approximately 1-2 minutes at room temperature. After it has dried the grid is ready for tissue mounting. The pen is also used in pretreating grids prior to mounting supporting films such as formvar and carbon; it minimizes dislodging, widening, or breaking of the support film.



Cat. No.	Description	Qty.
70624	Grid Coating Pen	each



Hot Pen – Wax Pen; A Tool for Separating Sections or Cauterizing

Powered by AA batteries. This pen helps to flatten and separate tissue sections and reduces compression in thin sections. Available in two models: Wax Pen 1 is powered by one AA battery; Wax Pen 2 is powered by two AA batteries. Both pens are using the same tip. Replacement tip (Cat. #72679-RT) is a straight one. Replacement tip (Cat. #72679-03) is a set of three different configurations: Straight, Hook, and 'U' Shaped Tips.

Cat #	Description	Length with Tip w/o Cap	w/Cap	Diameter	Pack
72678	Wax Pen 1 (A)	6½"	6¾"	¾", 18mm	each
72679	Wax Pen 2 (B)	8¾"	8¾"	¾", 18mm	each
72679-RT	Replacement Tip				each
72679-03	Replacement Tips			Set of Three Variable Tips	

Grid-Stick Kit

A helpful device for multi grid staining. If the instructions are followed carefully you can say good-bye to precipitate and dirt. The Grid Stick is made from a thin, but rigid alloy that does not react with commonly used organic solvents or stains. The stick itself measures 4mm wide, 75mm long and has a slot along its center with small undercut notches on one side to make grid removal simple. A small area on the top of each stick is reserved for identification.



The Grid Stick is coated with a specially-formulated pressure-sensitive adhesive. This adhesive is resistant to solvents used in conventional staining methods (e.g., water, alcohol, ethanol) and aggressively holds the grids in place during staining, emulsion coating, carbon coating, shadow casting, serial section collection, etc., yet will not remain on the grid once it is removed from the stick. During staining the grids are held in the same plane as the solution flow, minimizing the risk of breaking the formvar film and, or collecting surface debris. Grids may be stored, handled, and examined with minimal effort. For example, if your grids are on SynapTek Grid Sticks you can simply place the stick on the stage of a phase microscope, identify the material (you will see outlines of large cells), and determine its condition (i.e., holes in material, dirt on grids) in only a few seconds without disturbing a single grid. In short, you will find that the SynapTek Grid Stick is simple, easy to use, and most importantly, highly reliable.

SynapTek Grid-Stick consists of:

- 5 coated Grid Sticks
- 10 Staining Pipettes (modified)
- 2 flow-limiting Plugs and Bulbs
- Instructions

Cat. No.	Description	Qty.
71175	Grid-Stick Kit	each

Replacement Components:

71176	Grid-Stick, uncoated	10/pk
71177	Staining Pipettes with 2 plugs	20/pk
71178	Grid-Stick Glue (For recoating GridStick)	5ml

GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Staining & Mounting (continued)

Perfect Loop

Using this PERFECT LOOP, you can place your thin sections, cut on the ultramicrotome, easily on the grid mesh without creases.

**EMS
EXCLUSIVE**

The Perfect Loop allows you to pick up sections consistently without causing any damage to the sections. It is the only loop that is currently available where the outside diameter of the loop is the same as the grid and the inside diameter is slightly larger than the observation area of the electron microscope. The thickness is about 40 microns. Due to the fact that the loop and the grid are of the same diameter they are attracted to one another when in water and attach together through the surface tension of the water. Even if the section touches the inside of the grid during blotting the touching area is minor and, therefore, the section is not damaged. When the grid is removed from the loop the section remains in place without fail. The area equals the observation field (about 2mm diameter) of the electron microscope; thus pieces can be fully observed.

Perfect Loop for Ultra thin sections

Cat. No.	Description	Qty.
70944	Set of Handle & Loop	set
70945	Loop only	each
70946	Loop only	5/each
70948	Handle only	each

Perfect Loop for Light Microscopy (large sections)

The outside diameter of the loop is 7mm.

Cat. No.	Description	Qty.
70940	LM Set of Handle & Loop	set
70941	LM Loop only	each
70942	LM Loop only	5/each
70943	LM Loop Handle	each

Deluxe Perfect Loop

As in our standard this device allows you to pick up sections with ease. This set utilizes the Perfect Handle complete with protective collar.



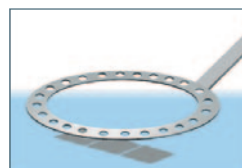
Cat. No.	Description	Qty.
70939	Deluxe Perfect Loop Set	set
70616-HD	Perfect Handle Only	each

Platinum Loop

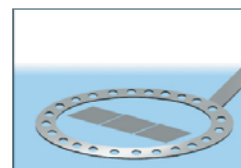
A perfect tool for the manipulation of samples before and during sample preparation in microscopy. This loop is made of high purity platinum and comes with or without handles. The thickness is 0.20mm and the diameter is 5 mm ID.



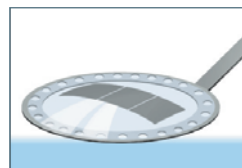
Cat. No.	Description	Qty.
70923-01	Platinum Loop and Handle, 5.0 mm ID	set
70923-02	PT Loop, 5.0 mm ID, 2.5 cm L	each
70922-08	Loop Handle, 6" L	each



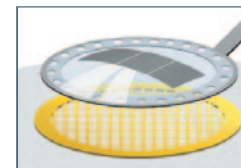
1. Center the LOOP above the sections



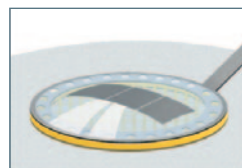
2. Slowly lower the LOOP over the sections and touch the water.



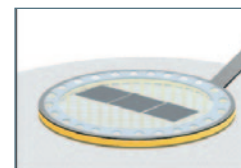
3. Gently lift up the LOOP with the sections in a droplet of water



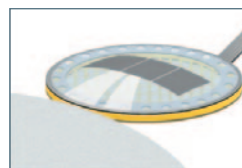
4. Lower the LOOP onto a grid and lift up again.



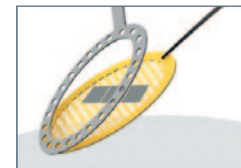
5. The grid holds to the LOOP by surface tension.



6. Lower the LOOP to the filter paper to remove water.



7. For coated grids, touch with filter paper to remove water.



8. Separate the grid from the LOOP with an eyelash.

Nichrome Loop and Handle

A perfect tool for the manipulation of samples before and during sample preparation in microscopy.

These nichrome loops come with or without handles and the wire comes in an assortment of internal diameters to accommodate many sample sizes.

The nichrome wire's composition is 60% Ni, 24% Fe Alloy, 16% Cr.



Cat. No.	Description	Qty.
70922-01	Nichrome Loop and Handle, 1.5 mm ID, 6.35 cm L	set
70922-02	Nichrome Loop and Handle, 3.5 mm ID, 6.35 cm L	set
70922-03	Nichrome Loop and Handle, 5.0 mm ID, 6.35 cm L	set
70922-04	Nichrome Loop, 1.5 mm ID	each
70922-05	Nichrome Loop, 3.5 mm ID	each
70922-06	Nichrome Loop, 5.0 mm ID	each
70922-07	Nichrome Wire, 30 gauge, 100 ft	each
70922-08	Loop Handle, 6" L	each

GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Staining & Mounting (continued)

Micro-Test Staining Dish



This staining dish is made from clear glass and has 10 cells in 2 rows of 5 each. Each cell is 2mm deep and holds 0.15ml of solution. Very useful in specimen preparation, EM staining, and Boerner-Jones-Lukens microfluocclulation test. Measurements: 108 X 57mm (4 1/4" x 2 1/4").

Cat. No.	Description	Qty.
71564	Micro-Test/Staining Dish	each

3-Well Porcelain Slide – Micro Spot Plate



Porcelain Micro Spot Plate is ideal for microchemical applications. With three concave depressions. Cavities measure 7/8" O.D. x 1/4" Deep (22 x 7mm). Plate overall measures 3 3/8"(L) x 1 1/8"(W) (85 x 34mm)

Cat. No.	Description	Qty.
71561-01	3-Well Slide, Porcelain	each
71561-06	3-Well Slide, Porcelain	6/pk

White Porcelain Plate



12 cavities on a white porcelain plate. Used for staining and color reactions. They measure: 4 7/8"(L)x3 1/2"(W) (118x90mm). Cavity depth: 1/4" (6.4mm).

Cat. No.	Description	Qty.
71562-01	White Porcelain Plate	each
71562-06	White Porcelain Plate	6/pk

Glazed Porcelain Plate



Our economical glazed porcelain plate is made from high purity raw material, uniform in quality and resistant to acids and alkalis. It can withstand sudden temperature changes without cracks, explosion or deformation. Under normal conditions, the glazed plate can sustain a temperature of up to 1050° C.

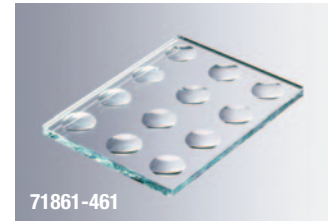
Available in two models:

1. 6 well with overall measurements of 3 1/4"(L) x 2 1/8"(W) x 3/8" thick, and
2. 12 wells with overall measurements of 4 1/2" (L) x 3 1/2" (W) x 1/2" thick.

Cat. No.	Description	Well Measures	Qty.
71575-06	6-Well	20mm Dia x 5mm Deep	each
71575-12	12-Well	20mm Dia x 5mm Deep	each

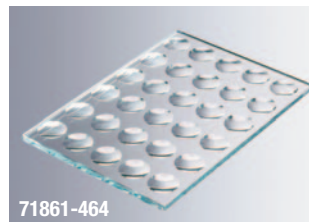
Marienfeld Superior™ Staining Plates

- Made of float glass
- With bevelled edges
- With clipped corners
- With ground and polished cavities



Cavities: approx. 20 to 22 mm diameter, approx. 2 mm depth

Cat No.	Cavities	Dimensions	Qty.
71861-460	6	130 x 100 x 6 mm	each
71861-461	12	130 x 100 x 6 mm	each
71861-462	24	130 x 160 x 6 mm	each



Cavities: approx. 24 mm diameter, approx. 3 mm depth

Cat No.	Cavities	Dimensions	Qty.
71861-463	24	130 x 200 x 6 mm	each
71861-464	30	130 x 200 x 6 mm	each

Matte surface, cavities: approx. 16 mm diameter, approx. 1.5 mm depth

Cat No.	Cavities	Dimensions	Qty.
71861-465	12	76 x 60 x 4 mm	5/pk

Pyrex® Plate

A 9 cavity Pyrex pressed plate which offers a clear view for observation by transmitted light. The plate measures: 4"(L)x3 3/8"(W) (100x85mm). The cavity is 1/4" (6.4mm) deep with a 7/8" (22mm) opening.



Cat. No.	Description	Qty.
71563-01	Pyrex Plate	each
71563-06	Pyrex Plate	6/pk

3-Cavities Spot Plates, LDPE

These spot plates have three depressions 21mm diameter x 7mm deep. The tray is 28mm x 85mm. Made from low density polyethylene and will withstand temperatures up to 80° C.



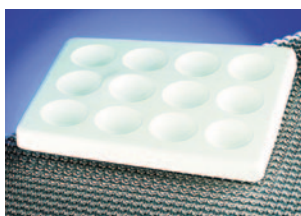
Cat. No.	Description	Qty.
71574-05	3-Cavities Spot Plate, Polypropylene	5/pk
71574-40	3-Cavities Spot Plate, Polypropylene	40/cs

GRID PREPARATION SUPPLIES AND ACCESSORIES

Grid Staining & Mounting (continued)

12 Cavities Spot Plate, Polypropylene

Very similar to the white porcelain plate, this PP plate comprises 12 cavities of approximately 1ml capacity and is economically priced. This plate is very high quality, unbreakable as well as autoclavable.



Cat. No.	Description	Qty.
71572-01	12-Cavities Spot Plate, Polypropylene	each
71572-10	12-Cavities Spot Plate, Polypropylene	10/cs

Silicone Staining Pad

Made from white silicone, a non-reactive material. Pad has 40 cells in 5 rows of 8 each. Each cell is half-sphere shaped with an opening of 6mm dia. and 5mm deep. A few drops of staining solution is added to the wells and grids are then immersed and retrieved as per staining procedure. A watch-glass plate comes with each dish to reduce oxygen and evaporation. Measures: 5"(L)x3"(W)x 1/2"(T) (127x76x13mm)



Cat. No.	Description	Qty.
71565	Silicone Staining Pad	each

Syracuse Watch Glass

A clear watch glass which measures 65mm (OD) x 50mm (ID) x 10mm (Deep). The glass is grooved and has a recessed bottom which allows for stacking and prevents scratching. It is ideal for staining and specimen preparation.



Cat. No.	Description	Qty.
71570-01	Syracuse Watch Glass	each
71570-06	Syracuse Watch Glass	6/pk

An EMS Exclusive...

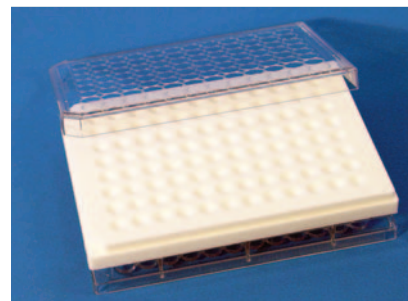
The EMS Staining Plate

The EMS Staining Plate for Electron Microscopy was developed by Dr. Miguel Berrios, at SUNY at Stony Brook, Dept of Pharmacological Sciences, School of Medicine, New York.

The chemical etching process, antibody incubations and final staining with heavy metal salts of each grid is performed in the small cone-shaped wells on the EMS staining plate.

The EMS Staining Plate for electron microscopy post-embedding staining and immunohistochemistry offers several advantages over all other commercially available staining devices. The base plate is a solid piece of chemical-resistant silicone 127.5mm long, 85.5mm wide, 11.5mm thick with 96 cone-shaped wells organized (like the microtitration plate) in parallel rows of eight, using the lid of a 96-well Falcon 3072 Microtest™ III Plate as a cover. The base has two notches to serve for orientation and a 1.5mm X 4.4mm deep lip where the cover rests. Each well is an inverted cone 7mm in diameter and 2mm deep. Grids either float or rest at the bottom of each well. The wells allow incubation of a grid in 12-60 microliters of solution without reagent loss due to adsorption or cross contamination, even when the plate is tilted up at 70°. Due to the shape of the well, the flat surface of the grids never come into contact with the walls of the well, both facilitating sample staining and grid recovery.

Reference: Berrios, Miguel; (1991), A Staining Plate For Electron Microscopy. 48: 90-92.



Silicone offers two advantages:

- Resistant to all chemicals and solvents
- During manipulation of the grids in the well there is no risk of damaging the fine points of the tweezers.

Cat. No.	Description	Qty.
71568	EMS Staining Plate	each

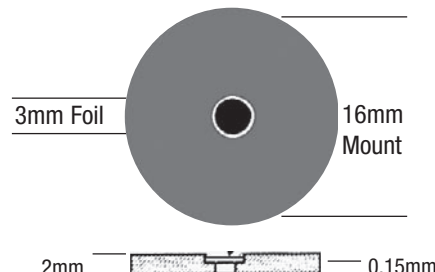
Pinholes

Copper Foil Pinholes

These pinholes are prepared from pure copper foil, 3mm in diameter, 25 microns thick. They possess very high roundness and edge retention. Blackened on one surface. Mounted in black anodized aluminum discs. Mounted in a recessed hole in an anodized holder, 16 mm in diameter.

Applications

- Spatial filtering. ■ Controlling the diameter of light beams
- Creating point light sources. ■ Image analysis. ■ Etc.



Cat. No.	Description	Qty.
PH-C1	Pin Hole 0.001mm (1µm) dia.	each
PH-C2	Pin Hole 0.002mm (2µm) dia.	each
PH-C5	Pin Hole 0.005mm (5µm) dia.	each
PH-10	Pin Hole 0.01mm (10µm) dia.	each
PH-C25	Pin Hole 0.025mm (25µm) dia.	each

Cat. No.	Description	Qty.
PH-C50	Pin Hole 0.05mm (50µm) dia.	each
PH-100	Pin Hole 0.1mm (100µm) dia.	each
PH-C250	Pin Hole 0.25mm (250µm) dia.	each
PH-C1000	Pin Hole 1.0mm (1000µm) dia.	each

Hole Range	Tolerance
101-500µm	+/- 2µm
25-100µm	+/- 1µm
1-25µm	+/- 0.5µm

GRID PREPARATION SUPPLIES AND ACCESSORIES

Vacuum Systems



III Vacuum Pick Up System

Handle delicate miniature objects without scratching, breaking or pinching. The system avoids contamination of parts and performs functions that tweezers does such as sorting, picking up, holding, carrying, and transferring. As well it is an alter-native way for handling cover slips without the use of forceps.

- Picks up grids faster and easier than tweezers – **WARNING: Never use this device on coated grids**
- Quiet operation
- Eliminates all tweezer damage to grids
- Good suction (produces 14" Hg vacuum and an air flow of 125 cubic inches/minute); Can pick up aluminum stubs
- Can be used as a tool to pick up glass slides, cover slips, wafers, thin film samples, etc.

Double-insulated (115-120V, 60Hz, 2-wire). Light weight, completely assembled and ready for immediate operation as soon as the proper tip is selected and installed. Vacuum is created at the tip by placing the finger over the control hole on the anodized aluminum vacuum pen. To break the vacuum, just remove your finger from the hole.

Vacuum Pick-up System includes:

Vacuum Pick-up System complete set: Vacuum Generator, Aluminum Vacuum Pen, Five Vacuum Tips, Set of seven Rubber Vacuum Cups (size ranging: 9/16", 1/2", 7/16", 3/8", 5/16", 1/4" and 3/16"), an In-Line Filter, and 4 ft (122 cm) of Vacuum Tubing.

Cat. No.	Description	Qty.
71894	Vacuum Pick-Up System, 115V/60Hz	each
71895	Vacuum Pick-Up System, 220/60Hz	each
71896	Vacuum Generator 115V	each
71897	Vacuum Generator 220V	each
71894-01	Vacuum Pick-up Pen only	each
71904-02	Vacuum in-line-filter 3/8" x 1 1/2"	each
Vacuum pick-up tips, Stainless steel, 1.5" long:		
71898	12 gauge, 0.109" (O.D.); 0.085" (I.D.)	each
71899	16 gauge, 0.065" (O.D.); 0.047" (I.D.)	each
71900	18 gauge, 0.050" (O.D.), 0.033" (I.D.)	each
71901	20 gauge, 0.035" (O.D.), 0.022" (I.D.)	each
71902	25 gauge, 0.020" (O.D.), 0.095" (I.D.)	each
71903	Vacuum suction cups 0.500" diameter	each
71904	Vacuum suction cups 0.250" diameter	each
71905	Vacuum suction cups 0.164" diameter	each
71906	5/16" (7.94mm) Vacuum Suction Cup	each
71907	1/4" (6.35mm) Vacuum Suction Cup	each
71909	Set of 7 Rubber Cups (9/16", 1/2", 7/16", 3/8", 5/16", 1/4", and 3/16")	7/set

III Pen Vac™

Pen-Vac™ is a new improved way to handle small, flat surface objects. Pen-Vac is ideal for EM work. It can be used to handle grids, pick up stubs, align membranes, work with glass slides, cover slips and much more. Holds up to one minute.



- Lifts up to 50 grams.
- Totally self-contained vacuum.
- Light-weight, less than 1oz.
- Fits in your pocket like a pen.
- Brushed aluminum body.
- Optional storage compartment for vacuum tips and cups.
- No power supply needed.
- Available in various sizes.
- Interchangeable vacuum probes.

Pen-Vac™ comes with:

- A variety of vacuum probes, with an attached vacuum cup and it is available with plastic or aluminum hubs. Straight and angled to suit your applications. The stainless steel needle portion of the probes are one-half inch long.
- We offer the Static Dissipative and Conductive Cups that provide ESD protection for electrostatic discharge of sensitive components. Cups comes in three sizes: 1/8" (3.17mm); 1/4" (6.35mm); and 3/8" (9.52mm).

Set consists of: One Pen with 6 Probes and Cups. (6 Probes: 3 angled, 1/8", 1/4", 3/8" and 3 straight 1/8", 1/4", 3/8")

71914	Complete Pen-Vac System	set
71915	Same as 71914 with Deluxe Case	set

Probes and Cups:

71916	1/8" Straight and Bent, Small	2/pk
71917	1/4" Straight and Bent, Medium	2/pk
71918	3/8" Straight and Bent, Large	2/pk

GRID PREPARATION SUPPLIES AND ACCESSORIES

Vacuum Systems (continued)

III ESD Vacuum Tool

Battery-free, hand-held vacuum pick up pen designed for the safe pick-up of SMD components during assembly, test and rework processes. With fountain-pen dimensions, Vampire grabs, lifts and places components in complete safety, aided by a powerful internal piston and a full ESD protection. A complete choice of tips designed for any size of SMD component helps the operator to have always the right tool in hand. Includes: pen, conductive metal straight needle, 45° angled metal needle, conductive rubber cup 4mm, conductive rubber cup 6mm, conductive rubber cup 9mm, and lubricant kit.

Cat. No.	Description	Qty.
71927-01	ESD Vacuum Tool Kit, includes: vacuum pen, straight conductive metal needle, 45° angled conductive metal needle, conductive rubber cup 4mm, conductive rubber cup 6mm, conductive rubber cup 9mm	kit
71927-02	ESD Vacuum tool replacement set: includes: straight conductive metal needle, 45° angled conductive metal needle, conductive rubber cup 4mm, conductive rubber cup 6mm, conductive rubber cup 9mm	set
71927-03	ESD Vacuum tool replacement set: includes: conductive rubber cup 4mm, conductive rubber cup 6mm, conductive rubber cup 9mm	set



Cat. No.	Description	Qty.
71927-04	Spare ESD 4mm cups	each
71927-05	Spare ESD 6mm cups	each
71927-06	Spare ESD 9mm cups	each
71927-07	Straight needle, ESD 4mm cup	each
71927-08	Straight needle, ESD 6mm cup	each
71927-09	Straight needle, ESD 9mm cup	each
71927-10	45° angle needle, ESD 4mm cup	each
71927-11	45° angle needle, ESD 6mm cup	each
71927-12	45° angle needle, ESD 9mm cup	each

III Porta-Wand®

The Porta-Wand kit comes with a non-removable 9.6V NiMH rechargeable battery and in-stand charger. Easy push-button on/off control. Replaceable internal air filter is accessible from the front of the tool. Internal exhaust filter ensures better than Class 1 performance. Indicator Light flashes when battery needs to be recharged, and also turn on when proper vacuum has been established.

Specifications:

Battery	Type: 9.6V NiMH, Rechargeable, Non-Removable Charge Time: 2 hrs.; Continuous Run Time: 2-3 hrs. Recharges: Up to 1000 Replacement: Factory Replaceable
Vacuum	15 to 20" of mercury (atmospheric pressure and elevation dependant)
Measurements	Wand: 7 x 1.2 x 0.85" (178 x 30 x 21mm) Stand: 4.5 x 2 x 3.5" (114 x 51 x 98mm)
Weight	Porta-Wand: 5.44 ounces (154 grams) Charger Stand: 10.5 ounces (298 grams) Transformer: 16 ounces (454 grams)
Operating Temp	10°C to 45°C
Charger Power Requirements	Supplied In-Stand Charger; Wall plug-in power supply 24 VDC @ 500ma. Barrel jack size 5.5mm OD x 2.1mm ID. Center pin positive.



Cat. No.	Description	Qty.
71928	Porta-Wand for up to 4" (100mm) wafers, with ESD-safe flat wafer tip and 115V In-stand Charger	each
71928-01	Porta-Wand for up to 6" (150mm) wafers, with ESD-safe flat wafer tip and 115V In-stand Charger	each
71928-02	Porta-Wand for up to 8" (200mm) wafers, with ESD-safe flat wafer tip and 115V In-stand Charger	each
71928-03	Porta-Wand for up to 12" (300mm) wafers, with ESD-safe flat wafer tip and 115V In-stand Charger	each
Porta-Wand with hard anodized wafer tip		
71928-04	Porta-Wand for up to 6" (150mm) wafers, with hard anodized wafer tip and 115V In-stand Charger	each
71928-05	Porta-Wand Air Intake Filters	5/pk

III Porta-Vac®

The Porta-Vac kit comes with a non-removable 9.6V NiMH rechargeable battery and in-stand charger. Easy push-button on/off control. Replaceable internal air filter is accessible from the front of the tool. Internal exhaust filter ensures better than Class 1 performance. Indicator Light flashes when battery needs to be recharged, and also turn on when proper vacuum has been established.

Specifications:

Battery	Type: 9.6V NiMH, Continuous Run Time: 3-4 hrs. Type: 9V Alkaline, Continuous Run Time: 12-15 hrs. Type: 9V Carbon, Continuous Run Time: 4-5 hrs. Type: 9V Lithium, Continuous Run Time: 36-40 hrs.
Vacuum	15 to 20" of mercury (atmospheric pressure and elevation dependant)
Measurements	Wand: 7.3 x 1.1 x 0.80" (185 x 28 x 20mm) With Rechargeable Battery: 7.92 x 1.1 x 0.80" (200.23 x 28 x 20mm)
Weight	With Battery: 6.03 ounces (171 grams)



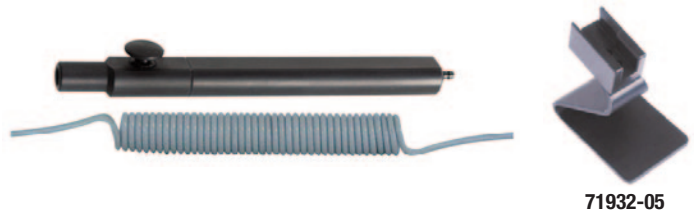
Cat. No.	Description	Qty.
71929	Porta-Vac II for up to 4" (100mm) wafers, with Molded PEEK wafer tip and 9V Disposable Battery	each
71929-01	Porta-Vac II for up to 6" (150mm) wafers, with Molded PEEK wafer tip and 9V Disposable Battery	each
71929-02	Porta-Vac II for up to 8" (200mm) wafers, with Molded PEEK wafer tip and 9V Disposable Battery	each
71929-03	Porta-Vac II 115V In-stand Charger and 9.6V Rechargeable NiMH Battery	each
71929-04	9.6V Rechargeable NiMH Battery	each
71929-05	Porta-Vac II Air Intake Filters	5/pk

GRID PREPARATION SUPPLIES AND ACCESSORIES

Vacuum Systems (continued)

ExP Vacuum Wand Kit

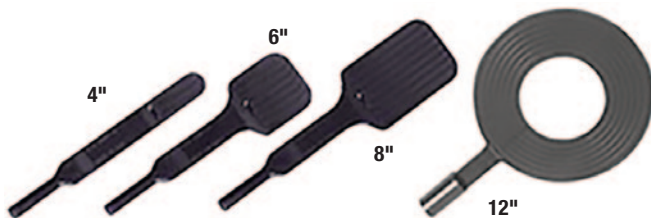
ExP Vacuum Wand Kits are a lower cost alternative to the Porta-Wand and Porta-Vac II systems, which share the same tips. Has a push-button to close the vacuum and release the wafer. The included stand keeps the button pressed when the wand is not in use. Comes complete with an 1/8" Inner Diameter coiled vacuum hose and a wafer tip. Must use a vacuum pump or vacuum line. Able to be used with our Vacuum Pick Up System.



Cat. No.	Description	Qty.
71932	ExP Vacuum Wand Kit for up to 4" (100mm) wafers, with Molded PEEK wafer tip, 1/8" coiled hose and stand	each
71932-01	ExP Vacuum Wand Kit for up to 6" (150mm) wafers, with Molded PEEK wafer tip, 1/8" coiled hose and stand	each
71932-02	ExP Vacuum Wand Kit for up to 8" (200mm) wafers, with Molded PEEK wafer tip, 1/8" coiled hose and stand	each
71932-03	ExP Vacuum Wand Kit for up to 12" (300mm) wafers, with Molded Flat wafer tip, 1/8" coiled hose and stand	each
71932-04	ExP Push Button Wand for 1/8" coiled hose	each
71932-05	Push Button Wand Holder	each

Molded PEEK ESD-Safe Wafer Tips

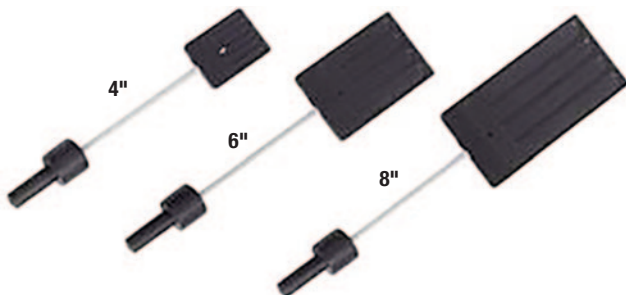
Made from PEEK, a high performance plastic and are able to be used in Porta-Wand, Porta-Vac II, and EMS Vacuum Wand Kits. Withstand temperatures up to 100°C. Thin profile to allow easy access to wafers.



Cat. No.	Description	Qty.
71935	Molded PEEK Wafer Tip for 4" (100mm) wafers	each
71935-01	Molded PEEK Wafer Tip for 6" (150mm) wafers	each
71935-02	Molded PEEK Wafer Tip for 8" (200mm) wafers	each
71935-03	Molded Flat Wafer Tip for 12" (300mm) wafers	each

Hard Anodized Wafer Tips

Made from hard anodized aluminum, these wafer tips are able to be used in the Porta-Wand, Porta-Vac II and EMS Vacuum Wand Kits. Withstand high temperatures up to 250°C. They feature a 3" long, straight stainless steel tube covered by a PTFE sleeve. The press-fit adapter is made from static dissipative plastic.



Cat. No.	Description	Qty.
71936	Hard Anodized Wafer Tip for 4" (100mm) wafers	each
71936-01	Hard Anodized Wafer Tip for 6" (150mm) wafers	each
71936-02	Hard Anodized Wafer Tip for 8" (200mm) wafers	each

Handi-Vac® Vacuum Cup



The Handi-Vac®-2 has an improved tip designed for better lifting capacity utilizing larger, non-marking vacuum cups. This new tip also enhances functionality and improves accuracy when picking and placing parts. It can be purchased with one static-dissipative cup available in three sizes: 3/8", 1/2" and 5/8". The entire vacuum tool is ESD-safe.

Cat. No.	Description	Qty.
71921-01	Handi-Vac-2, 3/8" (9.53mm) Vacuum Cup	each
71921-02	Handi-Vac-2 With 1/2" (12.7mm) Vacuum Cup	each
71921-03	Handi-Vac-2 With 5/8" (15.88mm) Vacuum Cup	each

Handi-Vac® Squeeze Bulb Kit

The Handi-Vac® Squeeze Bulb Kit is a versatile, cost-effective vacuum tool system that should be on every tool-bench.



Features:

- (1) 1/8" vacuum cup on bent probe
- (1) 1/4" vacuum cup on bent probe
- (1) 1/8" vacuum cup on straight probe
- (1) 3/8" vacuum cup on straight probe

Applications

SMT parts • Metal parts • Plastic parts • Smooth, nonporous-surfaces

This tool can be used with larger rubber vacuum cups ranging in size from 3/32" (2.38mm) to 3/4" (19.05mm) in diameter. Use the larger cups to pick up larger and heavier parts by placing them directly on the Handi-Vac tip without using a probe.

Cat. No.	Description	Qty.
71921-25	Handi-Vac® Squeeze Bulb Kit, includes:	each
	(1) 1/8" vacuum cup on bent probe	
	(1) 1/4" vacuum cup on bent probe	
	(1) 1/8" vacuum cup on straight probe	
	(1) 3/8" vacuum cup on straight probe	

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